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Fundamentals of Measurement Systems

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1.1 Introduction

Measurement techniques have been of immense importance ever since the start of human civilization, when measurements were first needed to regulate the transfer of goods in barter trade in order to ensure that exchanges were fair. The industrial revolution during the 19th century brought about a rapid development of new instruments and measurement techniques to satisfy the needs of industrialized production techniques. Since that time, there has been a large and rapid growth in new industrial technology. This has been particularly evident during the last part of the 20th century because of the many developments in electronics in general and computers in particular. In turn, this has required a parallel growth in new instruments and measurement techniques.

The massive growth in the application of computers to industrial process control and monitoring tasks has greatly expanded the requirement for instruments to measure, record, and control process variables. As modern production techniques dictate working to ever tighter accuracy limits, and as economic forces to reduce production costs become more severe, so the requirement for instruments to be both accurate and inexpensive becomes ever harder to satisfy. This latter problem is at the focal point of the research and development efforts of all instrument manufacturers. In the past few years, the most cost-effective means of improving instrument accuracy has been found in many cases to be the inclusion of digital computing power within instruments themselves. These intelligent instruments therefore feature prominently in current instrument manufacturers' catalogues.

This opening chapter covers some fundamental aspects of measurement. First, we look at how standard measurement units have evolved from the early units used in baster trade to the

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4 Chapter I

(a) Fundamental Units				
Quantity	Standard Unit	. Speeded		
Longth	mater			
Mass	hilogram	l lig		
Tame	mcond	5		
Electric current	ampere	A		
Temperature	lation	K		
Lannous	candela	cd		
Matter	mole	mal		
(b) Supplementary Fundamental Units				
Quantity	Standard Unit	Symbol		
Plane angle	radian	md		
Solid angle	steradian			

Table 1.2 Fundamental SI Units

1.3.1 Elements of a Manurement System

A measuring system exists to provide information about the physical value of some variable being measured. In simple cases, the system cast consist of only a single unit that gives an output reading or signal according to the magnitude of the unknown variable applied to it. However, in more complex measurement situations, a measuring system consists of several separate elements as shown in Figure 1.1. These components might be contained within one or more boxes, and the boxes holding individual measurement elements might be either close together or physically separats. The term measuring instrument is used commonly to describe a measurement system, whether it contains only one or many elements, and this term is widely used throughout this text.

The first element in any measuring system is the primary sensor: this gives an output that is a function of the measurand (the input applied to it). For most but not all sensors, this function is at least approximately linear. Some examples of primary sensors are a liquid-inglass thermometer, a thermocouple, and a strain gauge. In the case of a mercury-in-glass thermometer, because the output reading is given in terms of the level of the mercury, this particular primary sensor is also a complete measurement system in itself. However, in general, the primary sensor is only part of a measurement system. The types of primary sensors available for measuring a wide range of physical quantities are presented in the later chapters of this book.

Variable conversion elements are needed where the output variable of a primary transducer is in an inconvenient form and has to be converted to a more convenient form. For instance, the displacement-measuring strain gauge has an output in the form of a varying resistance. Because the resistance change causet be measured easily, it is converted to a change in voltage by a bridge circuit, which is a typical example of a variable conversion element. In some cases, the

Quantity	Rendered Unit	Syndeci	Derivation Paramés
Area	square rester	m	
Volume	cubic meter	ma	
Velocity	metre per second	m/s	
Acceleration	metre per second squared	m/s ²	
Angular velocity	radian per second	rad/s	
Angular acceleration	radiant per second squared	rad/s2	
Density	kilogram per cubic meter	lag/rm ³	
Specific volume	cubic motor par bilogram	m / ML	
Mass flow rate	kilogram per second	im/s	
Volume flow rate	cubic meter per second	m /s	
Force	newton	N	lig-m/s ²
Pressure	pascal	Pa	N/m ²
Torque	newton rinker	N-m	
Momentum	kilogram meter per second	lig-m/s	
Moment of inertia	kingsten mensi topared	lig-m ²	
Kinematic viscosity	square meter per second	m /s	
Dynamic viecosity	newton second per sq metre	N-s/m ²	
Work, energy, heat	elucy	J	N-m
Specific energy	joule per cubic meter	J/m ²	
Power	wett	W	J/s
Thermal conductivity	watt per meter Kelvin	W/m-K	
Electric charge	coulantb	С	As
Voltage, e.m.f., pot diff	volt	V	W/A
Electric field strength	volt per meter	V/m	
Electric resistance	ohm	Ω	V/A
Electric capacitance	farad	F	A-4/V
Electric inductance	hanry	н	V-6/A
Electric conductance	SIGMEN	5	AV
Resistanty	ohm meter	Q-m	
Permittivity	ferad per meter	F/m	
Permeability	henry per meter	H/m	
Current density	ampere per square meter	A/m ²	
Magnetic flui	wataw	Wb	¥48
Magnetic flux density	teele	T	Wb/m ²
Magnetic field strength	ampere per meter	A,m	
Frequency	hertz	He	57
Luminous flui	la men	in.	cd-ar
Luminance	candels per square mater	cd/m ²	
flumination	lui -	in .	lm/m ²
Molar volume	cubic meter per mole	-m ³ /mol	
Molarity	mela per kilogram	mol/hg	and the second second
Molar energy	joule par mole	J/mol	-

Table 1.3 Derived SI Unita

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Figure 1.1 Elements of a recasuring system.

parmary sensor and variable conversion element are combined; this combination is known as a transducer,⁶

Signal processing elements exist to improve the quality of the output of a measurement system in some way. A very common type of signal processing element is the electronic amplifier, which amplifies the output of the primary transducer or variable conversion element, thus improving the sensitivity and resolution of measurement. This element of a measuring system is particularly important where the primary transducer has a low output. For example, thermocouples have a typical output of only a few millivolts. Other types of signal processing elements are those that filter out induced noise and remove mean levels, etc. In some devices, signal processing is incorporated into a transducer, which is then known as a *transmitter*.⁹

In addition to these three components just mentioned, some measurement systems have one or two other components, first to transmit the signal to some remote point and second to display or record the signal if it is not fed automatically into a feedback control system. Signal transmission is needed when the observation or application point of the output of a measurement system is nome distance away from the site of the primary transducer. Sometimes, this separation is made solely for purposes of convenience, but more often, it follows from the physical inaccessibility or environmental unsuitability of the site of the primary transducer for mounting the signal presentation/recording unit. The signal transmission element has traditionally consisted of single or multicored cable, which is often screened to minimize signal corruption by induced electrical noise. However, fiber-optic cables are being used in ever-increasing numbers in modern installations, in part because of their lew transmission loss and imperviousness to the effects of electrical and rangeetic fields.

In some cases, the word "sensor" is used generically to order to both transducers and transmitters.

The final optional element in a measurement system is the point where the measured signal is atilized. In some cases, this element is omitted altogether because the measurement is used as part of an automatic control scheme, and the transmitted signal is fed directly into the control system. In other cases, this element in the measurement system takes the form either of a signal presentation unit or of a signal-recording unit. These take many forms according to the requirements of the particular measurement application, and the range of possible units is discussed more fully in Chapter 8.

1.3.2 Choosing Appropriate Measuring Instruments

The starting point in choosing the most suitable instrument to use for measurement of a particular quantity in a manufacturing plant or other system is specification of the instrument characteristics required, especially parameters such as desired measurement accuracy, resolution, sensitivity, and dynamic performance (see the next chapter for definitions of these). It is also essential to know the environmental conditions that the instrument will be subjected to, as some conditions will immediately either eliminate the possibility of using certain types of instruments or else will create a requirement for expensive protection of the instrument, It should also be noted that protection reduces the performance of some instruments, especially in terms of their dynamic characteristics (e.g., sheaths protecting the mocouples and resistance thermometers reduce their speed of response). Provision of this type of information usually requises the expert knowledge of personnel who are intimately acquainted with the operation of the manufacturing plant or system in question. Then, a skilled instrument engineer, having knowledge of all instauments available for measuring the quantity in question, will be able to evaluate the possible list of instruments in terms of their accuracy, cost, and suitability for the environmental conditions and thus choose the most appropriate instrument. As far as possible, measurement systems and instruments should be chosen that are as insensitive as possible to the operating environment, although this requirement is often difficult to meet because of cost and other performance considerations. The extent to which the measured system will be distarbed during the measuring process is another important factor in instrument choice. For example, significant pressure loss can be caused to the measured system in some techniques of flow mensurement.

Published literature is of considerable help is the choice of a suitable instrument for a particular measurement situation. Many books are available that give valuable assistance in the necessary evaluation by providing lists and data about all instruments available for measuring a range of physical quantities (e.g., the later chapters of this text). However, new techniques and instruments are being developed all the time, and therefore a good instrumentation engineer must keep abreast of the latent developments by reading the appropriate technical journals regularly.

B Chapter 1

The instrument characteristics discussed in the next chapter are the features that form the technical basis for a comparison between the relative merits of different instruments. Generally, the better the characteristics, the higher the cost. However, in comparing the cost and relative mitability of different instruments for a particular measurement nituation, considerations of durability, maintainability, and constancy of performance are also very important because the instrument chosen will often have to be capable of operating for long periods without performance degradation and a requirement for costly maintenance. In consequence of this, the initial cost of an instrument often has a low weighting in the evaluation exercise,

Cost is correlated very strongly with the performance of an instrument, as measured by its static characteristics. Increasing the accuracy or resolution of an instrument, for example, can only be done at a penalty of increasing its manufacturing cost. Instrument choice therefore proceeds by specifying the minimum characteristics required by a measurement situation and then searching manufacturers' catalogues to find an instrument whose characteristics match those required. To select an instrument with characteristics superior to those required would only mean paying more than necessary for a level of performance greater than that needed.

As well as purchase cost, other important factors in the assessment exercise are instrument durability and maintenance requirements. Assuming that one had \$20,000 to spend, one would not spend \$15,000 on a new motor car whose projected life was 5 years if a car of equivalent specification with a projected life of 10 years was available for \$20,000. Likewise, durability is an important consideration in the choice of instruments. The projected life of instruments often depends on the conditions in that the instrument will have to operate. Maintenance requirements must also be taken into account, as they also have cost implications.

As a general rule, a good assessment criterion is obtained if the sotal purchase cost and estimated maintenance costs of an instrument over its life are divided by the period of its expected life. The figure obtained is thus a cost per year. However, this rule becomes modified where instruments are being installed on a process whose life is expected to be limited, perhaps in the manufacture of a particular model of car. Then, the total costs can only be divided by the period of time that an instrument is expected to be used for, unless an alternative use for the instrument is envisaged at the end of this period.

To summarize therefore, instrument choice is a compromise among performance characteristics, reggedness and datability, maintenance requirements, and purchase cost. To carry out such an evaluation properly, the instrument engineer must have a wide knowledge of the range of instruments available for measuring particular physical quantities, and ho/the must also have a deep understanding of how manument characteristics are affected by particular measurement situations and operating conditions.

1.4 Measurement System Applications

Today, the techniques of measurement are of immense importance in most facets of human civilization. Present-day applications of measuring instruments can be classified into three major areas. The first of these is their use in regulating trade, applying instruments that measure physical quantities such as length, volume, and muss in terms of standard units. The particular instruments and transducers employed in such applications are included in the general description of instruments presented in the later chapters of this book.

The second application area of measuring instruments is in monitoring functions. These provide information that enables human beings to take some prescribed action accordingly. The gardener uses a thermometer to determine whether he should turn the heat on in his greenhouse or open the windows if it is too hot. Regular study of a barometer allows us to decide whether we should take our umbrellas if we are planning to go out for a few hours. While there are thus many uses of instrumentation in our normal domestic lives, the majority of monitoring functions exist to provide the information necessary to allow a human being to control some industrial operation or process. In a chemical process, for instance, the progress of chemical reactions is indicated by the measurement of temperatures and pressares at various points, and such measurements allow the operator to make correct decisions regarding the electrical supply to heaters, cooling water flows, valve positions, and so on. One other important use of monitoring instruments is in calibrating the instruments used in the automatic process control systems described here.

Use as part of automatic feedback control systems forms the third application area of measurement systems. Figure 1.2 shows a functional block diagram of a simple temperature control system in which temperature T_n of a room is maintained at reference value T_n. The value



Elements of a simple closed-loop control system.

of the controlled variable, T_{a} , as determined by a temperature-measuring device, is compared with the reference value, T_{a} , and the difference, e, is applied as an error signal to the heater. The heater then modifies the room temperature until $T_{a} = T_{d}$. The characteristics of the measuring instruments used in any feedback control system are of fundamental importance to the quality of control achieved. The accuracy and resolution with which an output variable of a process is controlled can never be better than the accuracy and resolution of the measuring instruments used. This is a very important principle, but one that is often discussed inadequately in many texts on automatic control systems. Such texts explore the theoretical aspects of control system design in considerable depth, but fail to give sufficient emphasis to the fact that all gain and phase margin performance calculations are entirely dependent on the quality of the process measurements obtained.

1.5 Summary

This opening chapter covered some fundamental aspects of measurement systems. First, we looked at the importance of having standard measurement units and how these have evolved into the Imperial and metric systems of units. We then went on to look at the main aspects of measurement system design and, in particular, what the main components in a measurement system are and how these are chosen for particular measurement requirements. Finally, we had a brief look at the range of applications of measurement systems.

1.6 Problems

- 1.1. How have systems of measurement units evolved over the years?
- 1.2. What are the main elements in a measurement system and what are their functions? Which elements are not needed in nome measurement systems and why are they not needed?
- 1.3. What are the main factors governing the choice of a measuring instrument for a given application?
- 1.4. Name and discuss three application areas for measurement systems.

CHAPTER 2

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2.1 Introduction

Two of the important aspects of measurement covered in the opening chapter concerned how to choose appropriate instruments for a particular application and a review of the main applications of measurement. Both of these activities require knowledge of the characteristics of different classes of instruments and, in particular, how these different classes of instrument perform in different applications and operating environments.

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We therefore start this chapter by reviewing the various classes of instruments that exist. We see first of all that instruments can be divided between active and passive ones according to whether they have an energy source contained within them. The next distinction is between sull-type instruments that require adjustment until a datum level is reached and deflection-type instruments that give an output measurement in the form of either a deflection of a pointer against a scale or a numerical display. The third distinction covered is between analogue and digital instruments, which differ according to whether the output varies continuously tanalogue instruments, which differ according to whether the output varies continuously tanalogue instruments or in discrete steps (digital instrument). Fourth, we look at the distinction between instruments that are morely indicators and those that have a signal output. Indicators give some visual or audio indication of the magnitude of the measured quantity and are commonly found in the process industries. Instruments with a signal output are commonly found as part of automatic control systems. The final distinction we consider is between smart and nonsmart instruments. Smart, often known as intelligent, instruments are very important today and predominate in most measurement applications. Because of their importance, they are given more detailed consideration later in Chapter 11.

The second part of this chapter looks at the various attributes of instruments that determine their performance and suitability for different measurement requirements and applications. We look first of all at the static characteristics of instruments. These are their steady-state attributes (when the output measurement value has satiled to a constant reading after any initial varying output) such as accuracy, measurement sensitivity, and resistance to errors caused by variations in their operating environment. We then go on to look at the dynamic characteristics of instruments. This describes their behavior following the time that the measured quantity changes value ap until the time when the output seading attains a steady value. Various kinds of dynamic behavior can be observed in different instruments ranging from an output that varies slowly until it reaches a final constant value to an output that oucillates about the final value until a steady reading is obtained. The dynamic characteristics are a very important factor in deciding on the suitability of an instrument for a particular measurement application. Finally, at the end of the chapter, we also briefly consider the issue of instrument calibration, although this is considered in much greater detail later in Chapter 4.

2.2 Review of Instrument Types

Instruments can be subdivided into separate classes according to several criteria. These subclassifications are useful in broadly establishing several attributes of particular instruments such as accuracy, cost, and general applicability to different applications.

2.2.1 Active and Passave Instruments

Instruments are divided into active or passive ones according to whether instrument output is produced entirely by the quantity being measured or whether the quantity being measured simply modulates the magnitude of some external power source. This is illustrated by examples.

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Passive pressure gauge.

An example of a passive instrument is the pressure-measuring device shown in Figure 2.1. The pressure of the fluid is translated into snovement of a pointer against a scale. The energy expended in moving the pointer is derived entirely from the change in pressure measured: there are no other energy inputs to the system.

An example of an active instrument is a float-type petrol tank level indicator as sketched in Figure 2.2. Here, the change in petrol level moves a potentiometer arm, and the output signal consists of a proportion of the external voltage source applied across the two ends of the potentiometer. The energy in the output signal comes from the external power source: the primary transducer float system is merely modulating the value of the voltage from this external power source.

In active instruments, the external power source is usually in electrical form, but in some cases, it can be other forms of energy, such as a pneumatic or hydraulic one.

One very important difference between active and passive instruments is the level of measurement resolution that can be obtained. With the simple pressure gauge shows, the



Petrol-task level indicator

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amount of movement made by the pointer for a particular pressure change is closely defined by the nature of the instrument. While it is possible to increase measurement resolution by making the pointer larger, such that the pointer up moves through a larger arc, the scope for such improvement is clearly restricted by the practical limit of how long the pointer can conveniently be. In an active instrument, however, adjustment of the magnitude of the external energy input allows much greater control over measurement resolution. While the scope for improving measurement resolution is much greater incidentally, it is not infinite because of limitations placed on the magnitude of the external energy input, in consideration of heating effects and for safety reasons.

In terms of cost, passive instruments are normally of a more simple construction than active ones and are therefore less expensive to manufacture. Therefore, a choice between active and passive instruments for a particular application involves carefully balancing the measurement resolution requirements against cost.

2.2.2 Null-Type and Deflection-Type Instruments

The pressure gauge just mentioned is a good example of a deflection type of instrument, where the value of the quantity being measured is displayed in terms of the amount of movement of a pointer. An alternative type of pressure gauge is the dead-weight gauge shown in Figure 2.3, which is a null-type instrument. Here, weights are put on top of the piston until the downward force balances the fluid pressure. Weights are added until the piston reaches a datum level, known as the null point. Pressure measurement is made in terms of the value of the weights needed to reach this null position.

The accuracy of these two instruments depends on different things. For the first one it depends on the linearity and calibration of the spring, whereas for the second it relies on calibration of the weights. As calibration of weights is much easier than careful choice and calibration of a linear-characteristic spring, this means that the second type of instrument will normally be the more accurate. This is in accordance with the general rule that null-type instruments are more accurate than deflection types.



In terms of usage, a deflection-type instrument is clearly more convenient. It is far simpler to read the position of a pointer against a scale than to add and subtract weights until a null point is reached. A deflection-type instrument is therefore the one that would normally be used in the workplace. However, for calibration duties, a null-type instrument is preferable because of its superior accuracy. The extra effort required to use such an instrument is perfectly acceptable in this case because of the infraquent nature of calibration operations.

2.2.3 Analogue and Digital Instruments

An analogue instrument gives an output that varies continuously as the quantity being measured changes. The output can have an infinite number of values within the range that the instrument is designed to measure. The deflection-type of pressure gauge described earlier in this chapter (Figure 2.1) is a good example of an analogue instrument. As the input value changes, the pointer moves with a smooth continuous motion. While the pointer can therefore be in an infinite number of positions within its range of movement, the number of different positions that the eye can discriminate between is strictly limited; this discrimination is dependent on how large the scale is and how finely it is divided.

A digital instrument has an output that varies is discrete steps and so can only have a finite number of values. The rev counter sketched in Figure 2.4 is an example of a digital instrument. A care is attached to the revolving body whose motion is being measured, and on each revolution the care opens and closes a switch. The switching operations are counted by an electronic counter. This system can only count whole revolutions and cannot discriminate any motion that is less than a full revolution.

The distinction between analogue and digital instruments has become particularly important with rapid growth in the application of microcomputers to automatic control systems. Any digital computer system, of which the microcomputer is but one example, performs its computations in digital form. An instrument whose output is in digital form is therefore particularly advantageous in such applications, as it can be interfaced directly to the control



comparer. Analogue instruments must be interfaced to the microcompater by an analogueto-digital (A/D) converter, which converts the analogue output signal from the instrument into an equivalent digital quantity that can be read into the computer. This conversion has neveral disadvantages. First, the A/D converter adds a significant cost to the system. Second, a finite time is involved in the process of converting an analogue signal to a digital quantity, and this time can be critical in the control of fast processes where the accuracy of control depends on the speed of the controlling computer. Degrading the speed of operation of the control computer by imposing a requirement for A/D conversion thus impairs the accuracy by which the process is controlled.

2.2.4 Indicating Instruments and Instruments with a Signal Output

The final way in which instruments can be divided is between those that merely give an audio or visual indication of the magnitude of the physical quantity measured and those that give an output in the form of a measurement signal whose magnitude is proportional to the measured quantity.

The class of indicating instruments normally includes all null-type instruments and most passive ones. Indicators can also be further divided into those that have an analogue output and those that have a digital display. A common analogue indicator is the liquid-in-glass thermometer. Another common indicating device, which exists in both analogue and digital forms, is the bathroom scale. The older mechanical form of this is an analogue type of instrument that gives an output consisting of a rotating pointer moving against a scale (or sometimes a rotating scale moving against a pointer). More secent electronic forms of bathroom scales have a digital output consisting of numbers presented on an electronic display. One major drawback with indicating devices is that human intervention is required to read and record a measurement. This process is particularly prone to error in the case of analogue output displays, although digital displays are not very prone to error unless the human reader is careless.

Instruments that have a signal-type output are used commonly as part of automatic control systems. In other circumstances, they can also be found in measurement systems where the output measurement signal is recorded in some way for later use. This subject is covered in later chapters. Usually, the measurement signal isvolved is an electrical voltage, but it can take other forms in some systems, such as an electrical current, an optical signal, or a pneumatic signal.

2.2.5 Smirt and Nonsmart Instruments

The advent of the microprocessor has created a new division in instruments between those that do incorporate a microprocessor (smart) and those that don't. Smart devices are considered in detail in Chapter 11.

2.3 Static Characteristics of Instruments

If we have a thermometer in a room and its reading shows a temperature of 20°C, then it does not really matter whether the true temperature of the room is 19.5 or 20.5°C. Such small variations around 20°C are too small to affect whether we feel warm enough or not. Our bodies cannot discriminate between such close levels of temperature and therefore a thermometer with an inaccuracy of ± 0.5 °C is perfectly adequate. If we had to measure the temperature of certain chemical processes, however, a variation of 0.5°C raight have a significant effect on the rate of reaction or even the products of a process. A measurement inaccuracy much less than ± 0.5 °C is therefore clearly required.

Accuracy of measurement is thus one consideration in the choice of instrument for a particular application. Other parameters, such as sensitivity, linearity, and the reaction to ambient temperature changes, are further considerations. These attributes are collectively known as the static characteristics of instruments and are given in the data sheet for a particular instrument. It is important to note that values quoted for instrument characteristics is such a data sheet only apply when the instrument is used under specified standard calibration conditions. Due allowance must be made for variations in the characteristics when the instrument is used in other conditions.

The various static characteristics are defined in the following paragraphs.

2.3.1 Accuracy and Inaccuracy (Measurement Uncertainty)

The accuracy of an instrument is a measure of how close the output reading of the instrument is to the correct value. In practice, it is more usual to quote the *inaccuracy* or *measurement uncertainty* value rather than the accuracy value for an instrument. Inaccuracy or measurement uncertainty is the extent to which a reading might be wrong and is often quoted as a percentage of the full-scale (f.s.) reading of an instrument.

The aforementioned example carries a very important message. Because the maximum measurement error in an instrument is usually related to the full-scale reading of the instrument, measuring quantities that are substantially less than the full-scale reading means that the possible measurement error is amplified. For this reason, it is an important system design rule that instruments are chosen such that their range is appropriate to the spassified of values being measured in order that the best possible accuracy is maintained in instrument evolves. Cleants if we are measuring pressures with expected values between 0 and 1 bar, we would not use instrument with a measurement range of 0-10 bar.

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III Example 2.1

A pressure gauge with a measurement range of 0–10 bar has a quoted inaccuracy of $\pm 1.0\%$ f.s. ($\pm 1\%$ of full-scale reading).

- (a) What is the maximum measurement error expected for this instrument?
- (b) What is the likely measurement error expressed as a percentage of the output reading if this pressure gauge is measuring a pressure of 1 bar?

Solution

- (a) The maximum error expected in any measurement reading is 1.0% of the full-scale reading, which is 10 bar for this particular instrument. Hence, the maximum likely error is 1.0% × 10 bar = 0.1 bar.
- (b) The maximum measurement error is a constant value related to the full-scale reading of the instrument, irrespective of the magnitude of the quantity that the instrument is actually measuring. In this case, as worked out earlier, the magnitude of the error is 0.1 bar. Thus, when measuring a pressure of 1 bar, the maximum possible error of 0.1 bar is 10% of the measurement value.

2.3.2 Precision/Repetability/Reproducibility

Precision is a term that describes an instrument's degree of freedom from random errors. If a large number of readings are taken of the same quantity by a bigh-precision instrument, then the spread of readings will be very small. Precision is often, although incorrectly, confused with accuracy. High precision does not imply anything about measurement accuracy. A high-precision instrument may have a low accuracy. Low accuracy measurements from a high-precision instrument are normally caused by a bias in the measurements, which is removable by recalibration.

The terms repeatability and reproducibility mean approximately the same but are applied in different contexts, as given later. Repeatability describes the closeness of output readings when the same input is applied repetitively over a short period of time, with the same measurement conditions, same instrument and observer, same location, and same conditions of use maintained throughout. Reproducibility describes the closeness of output readings for the same input when there are changes in the method of measurement, observer, measuring instrument, location, conditions of use, and time of measurement. Both terms thus describe the apread of output readings for the same input. This spread is referred to as repeatability if the measurement conditions are constant and as reproducibility if the measurement conditions vary.

The degree of repostability or reproducibility in measurements from an instrument is an alternative way of expressing its precision. Figure 2.5 illustrates this more clearly by showing results of tests on three industrial robots programmed to place components at a particular point on a table. The target point was at the center of the concentric circles shown, and black dots represent points where each robot actually deposited components at each attempt. Both the accuracy and the precision of Robot 1 are shown to be low in this trial. Robot 2 consistently pats the component down at approximately the same place but this is the wrong point. Therefore, it has high precision but low accuracy. Finally, Robot 3 has both high precision and high accuracy because it consistently places the component at the correct target position.









2.3.3 Tolerance

Tolerance is a term that is closely related to accuracy and defines the maximum error that is to be expected in some value. While it is not, strictly speaking, a static characteristic of measuring instruments, it is mentioned here because the accuracy of some instruments is sometimes quoted as a tolerance value. When used correctly, tolerance describes the maximum deviation of a manufactured component from some specified value. For instance, crankshafts are machined with a diameter tolerance quoted as so many micrometers (10⁻⁶ m), and electric circuit components such as resistors have tolerances of perhaps 5%.

Example 2.2

A packet of resistors bought in an electronics component shop gives the nominal resistance value as 1000 Ω and the manufacturing tolerance as \pm 5%. If one resistor is chosen at random from the packet, what is the minimum and maximum resistance value that this particular resistor is likely to have?

Solution

The minimum likely value is $1000 \Omega - 5\% = 950 \Omega$. The maximum likely value is $1000 \Omega + 5\% = 1050 \Omega$.

2.3.4 Range or Span

The range or span of an instrument defines the minimum and maximum values of a quantity that the instrument is designed to measure.

2.3.5 Linearity

It is normally desirable that the output reading of an instrument is linearly proportional to the quantity being measured. The Xs marked on Figure 2.6 show a plot of typical output readings of an instrument when a sequence of input quantities are applied to it. Normal procedure is to draw a good fit straight line through the Xs, as shown in Figure 2.6, (While this can often be done with reasonable accuracy by eye, it is always preferable to apply a mathematical least-squares line-fitting technique, as described in Chapter 8.) Nonlinearity is then defined as the maximum deviation of any of the output readings marked X from this straight line. Nonlinearity is usually expressed as a percentage of full-scale reading.



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Instrument output characteristic.

2.3.6 Sansitivity of Measurement

The sensitivity of measurement is a measure of the change in instrument output that occurs when the quantity being measured changes by a given amount. Thus, sensitivity is the ratio:

> scale deflection value of measurand producing deflection

The sensitivity of measurement is therefore the slope of the straight line drawn on Figure 2.6. If, for example, a pressure of 2 bar produces a deflection of 10 degrees in a pressure transducer, the sensitivity of the instrument is 5 degrees/bar (assuming that the deflection is zero with zero pressure applied).

(I Example 2.3

The following resistance values of a platinum resistance thermometer were measured at a range of temperatures. Determine the measurement sensitivity of the instrument in ohms/ 'C.

Resistance (1)	Temperature (*C)
307	200
314	230
321	260
328	290

Solution

If these values are plotted on a graph, the straight-line relationship between resistance change and temperature change is obvious.

For a change in temperature of 30 °C, the change in resistance is 7 Ω . Hence the measurement sensitivity = 7/30 = 0.233 $\Omega/^{\circ}$ C.

2.3.7 Threshold

If the input to an instrument is increased gradually from zero, the input will have to reach a certain minimum level before the change in the instrument output reading is of a large enough magnitude to be detectable. This minimum level of input is known as the threshold of the instrument. Manufacturers vary in the way that they specify threshold for instruments. Some quote absolute values, whereas others quote threshold as a percentage of full-scale readings. As an illustration, a car speedometer typically has a threshold of about 15 km/h. This means that, if the vehicle starts from rest and accelerates, no output reading is observed on the speedometer until the speed reaches 15 km/h.

2.3.8 Resolution

When an instrument is showing a particular output reading, there is a lower limit on the magnitude of the change in the input measured quantity that produces an observable change in the instrument output. Like threshold, resolution is sometimes specified as an absolute value and sometimes as a percentage of f.a. deflection. One of the major factors influencing the resolution of an instrument is how finely its output scale is divided into subdivisions. Using a car speedometer as an example again, this has subdivisions of typically 20 km/h. This means that when the needle is between the scale markings, we cannot estimate speed more accurately than to the nearest 5 km/h. This value of 5 km/h thus represents the resolution of the instrument.

2.3.9 Sensitivity to Disturbance

All calibrations and specifications of an instrument are only valid under controlled conditions of temperature, pressure, and so on. These standard ambient conditions are usually defined in the instrument specification. As variations occur in the ambient temperature, certain static instrument characteristics change, and the sensitivity to disturbance is a measure of the magnitude of this change. Such covironmental changes affect instruments in two main ways, known as zero drift and aensitivity drift. Zero drift is sometimes known by the alternative term, bins.

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Zero drift or bias describes the effect where the zero reading of an instrument is modified by change in ambient conditions. This causes a constant error that exists over the full range or measurement of the instrument. The mechanical form of a bathroom scale is a common example of an instrument prone to zero drift. It is quite usual to find that there is a reading of perhaps 1 kg with no one on the scale. If someone of known weight 70 kg were to get on the scale, the reading would be 71 kg, and if someone of known weight 100 kg were to get on the scale, the reading would be 101 kg. Zero drift is normally removable by calibration. In the case of the bathroom scale just described, a thurabwheel is usually provided that can be turned until the reading is zero with the scales uslonded, thus removing zero drift.

The typical unit by which such zero drift is measured is volts/°C. This is often called the zero drift coefficient related to temperature changes. If the characteristic of an instrument is sensitive to neveral environmental parameters, then it will have several zero drift coefficients, one for each environmental parameter. A typical change in the output characteristic of a pressure parameter subject to zero drift is shown in Figure 2.7a.





Sensitivity drift (also known as at ale factor drift) defines the amount by which an instrument's neastivity of measurement varies as ambient conditions change. It is quantified by sensitivity drift coefficients that define how much drift there is for a unit change in each environmental parameter that the instrument characteristics are sensitive to. Many components within an instrument are affected by environmental fluctuations, such as temperature changes: for instance, the modulus of elasticity of a spring is temperature dependent. Figure 2.7b shows what effect genesitivity drift can have on the output characteristic of an instrument. Sensitivity drift is measured in units of the form (angular degree/bar)/° C. If an instrument suffers both zero drift and neastivity drift at the same time, then the typical modification of the output characteristic is abown in Figure 2.7c,

Example 2.4

The following table shows output measurements of a voltmeter under two sets of conditions:

- (a) Use in an environment kept at 20°C which is the temperature that it was calibrated at.
- (b) Use in an environment at a temperature of 50°C.

Voltage readings at calibration temperature	Voltage readings at
of 20 °C (mound correct)	temperature of 50 C
10.2	10.5
20.3	20.6
30.7	40.0
40.8	50.1

Determine the zero drift when it is used in the 50 °C environment, assuming that the measurement values when it was used in the 20°C environment are correct. Also calculate the zero drift coefficient.

Solution

Zero drift at the temperature of 50°C is the constant difference between the pairs of output readings, that is, 0.3 volts.

The zero drift coefficient is the magnitude of drift (0.3 volts) divided by the magnitude of the temperature change causing the drift (30°C). Thus the zero drift coefficient is 0.3/30 = 0.01 volts/°C.

Example 2.5

A spring balance is calibrated in an environment at a temperature of 20°C and has the following deflection/load characteristic:

Load (kg)	0	1	2	3
Deflection (mm)	0	20	40	60

It is then used in an environment at a temperature of 30°C, and the following deflection/ load characteristic is measured:

Load (kg)		1	2	3
Deflection (mm)	5	27	49	71

Determine the zero drift and sensitivity drift per C change in ambient temperature.

Solution

At 20°C, deflection/load characteristic is a straight line. Sensitivity = 20 mm/kg. At 30°C, deflection/load characteristic is still a straight line. Sensitivity = 22 mm/kg. Zero drift (bias) = 5 mm (the no-load deflection) Sensitivity drift = 2 mm/kg Zero drift/C = 5/10 = 0.5 mm/ C

Sensitivity drift/ C = 2/10 = 0.2 (mm/kg)/C

2.3.10 Hysteresis Effects

Figure 2.8 illustrates the output characteristic of an instrument that exhibits hysteresis. If the input measured quantity to the instrument is increased steadily from a negative value, the output reading varies in the manner shown in curve A. If the input variable is then decreased itendily, the output varies in the manner shown in curve B. The noncoincidence between these loading and unloading curves is known as hysteresis. Two quantities are defined, maximum input hysteresis and maximum output hysteresis, as shown in Figure 2.8. These are normally expressed as a percentage of the full-scale input or output reading, respectively.

Hysteresis is found most commonly in instruments that contain springs, such as a passive pressure gauge (Figure 2.1) and a Prony brake (used for measuring torque). It is also evident when friction forces in a system have different magnitudes depending on the direction of movement, such as in the pendulum-scale mass-measuring device. Devices such as the mechanical flyholi (a device for measuring notational velocity) suffer hysteresis from both of the aforementioned tources because they have fraction in moving parts and also contain a spring. Hysteresis can also



Instrument characteristic with hysteresis.

accur in instruments that contain electrical windings formed round an iron core, due to magnetic hysteresis in the iron. This occurs in devices such as the variable inductance displacement transducer, the linear variable differential transformer, and the rotary differential transformer.

2.3.11 Deed Spece

Dead space is defined as the range of different input values over which there is no change in output value. Any instrument that exhibits hysteresis also displays dead space, as marked on Figure 2.8. Some instruments that do not suffer from any significant hysteresis can still exhibit a dead space in their output characteristics, however, Backlash in gears is a typical cause of dead space and results in the nort of instrument output characteristic shown in Figure 2.9. Backlash is commonly experienced in gear sets used to convert between translational and rotational motion (which is a common technique used to measure translational velocity).

2.4 Dynamic Characteristics of Instruments

The static characteristics of measuring instruments are concerned only with the steady-state reading that the instrument settles down to, such as accuracy of the reading.

The dynamic characteristics of a measuring instrument describe its behavior between the time a measured quantity changes value and the time when the instrument output attains a stoody value in response. As with static characteristics, any values for dynamic characteristics quoted in instrument Despres and Performance Characteristics 27

Instrument characteristic with dead space.

data sheets only apply when the instrument is used under specified environmental conditions. Outside these calibration conditions, some variation in the dynamic parameters can be expected.

In any linear, time-invariant measuring system, the following general relation can be written between input and output for time (t) > 0;

$$a_{n}\frac{d^{n}q_{n}}{dt^{n}} + a_{n-1}\frac{dt^{n-1}q_{n}}{dt^{n-1}} + \dots + a_{1}\frac{dq_{n}}{dt} + a_{0}q_{n} = b_{m}\frac{dt^{n}q_{1}}{dt^{m}} + b_{m-1}\frac{dt^{n-1}q_{1}}{dt^{m-1}} + \dots + b_{1}\frac{dq_{n}}{dt} + b_{0}q_{n}$$
(2.1)

where q_i is the measured quantity, q_o is the output sending, and $a_0 \dots a_n$, $b_0 \dots b_m$ are constants.

The render whose mathematical background is such that Equation (2.1) appears dounting should not worry unduly, as only certain special, simplified cases of it are applicable in normal measurement situations. The major point of importance is to have a practical appreciation of the manner in which various different types of instruments respond when the measurand applied to them varies.

If we limit consideration to that of step changes in the measured quantity only, then Equation (2.1) reduces to

$$a_{\sigma} \frac{d^{\sigma} q_{\sigma}}{dt^{\sigma}} + a_{\sigma-1} \frac{d^{\sigma-1} q_{\sigma}}{dt^{\sigma-1}} + \dots + a_{3} \frac{dq_{\sigma}}{dt} + a_{0}q_{\sigma} = b_{0}q_{0}.$$
 (2.2)

Finither simplification can be made by taking certain special cases of Equation (2.2), which collectively apply to nearly all measurement systems.

2.4.1 Zero-Order Instrument

If all the coefficients a... an other than an in Equation (2.2) are assured zero, then

$$a_0 q_0 = b_0 q_1$$
 or $q_0 = b_0 q_1 / a_0 = K q_1$. (2.3)

where K is a constant known as the instrument assistivity as defined earlier.

Any instrument that behaves according to Equation (2.3) is said to be of a zero-order type. Following a step change in the measured quantity at time *t*, the instrument output moves immediately to a new value at the same time instant *t*, as shown in Figure 2.10. A potentiometer, which measures motion, is a good example of such an instrument, where the output voltage changes instantaneously as the slider is displaced along the potentiometer track.

2.4.2 First-Order Instrument

If all the coefficients a2 ... an except for an and a1 are assumed zero in Equation (2.2) then

$$a_1 \frac{dq_*}{dt} + a_0 q_* = b_0 q_i. \tag{2.4}$$

Any instrument that behaves according to Equation (2.4) is known as a first-order instrument. If d/dt is replaced by the D operator in Equation (2.4), we get

$$a_1Dq_0 + a_0q_0 = b_0q_0$$



and scarranging this then gives

$$q_{\mu} = \frac{(b_0/a_0)q_i}{[1 + (a_1/a_0)D]}.$$
 (2.5)

Defining $K = h_0/a_0$ as the static sensitivity and $\tau = a_1/a_0$ as the time constant of the system. Equation (2.5) becomes

$$q_{\rho} = \frac{L_{\phi}}{1 + zD}.$$
 (2.6)

If Equation (2.6) is solved analytically, the output quantity q_0 in response to a step change in q_1 at time t varies with time in the manner shown in Figure 2.11. The time constant τ of the step response is time taken for the output quantity q_0 to reach 63% of its final value.

The thermocouple (see Chapter 14) is a good example of a first-order instrument, it is well known that if a thermocouple at room temperature is plunged into boiling water, the output e.m.f. does not rise instantaneously to a level indicating 100°C, but instead approaches a reading indicating 100°C in a manner similar to that shows in Figure 2.11.

A large number of other instruments also belong to this first-order class: this is of particular importance in control systems where it is necessary to take account of the time lag that occurs between a measured quantity changing in value and the measuring instrument indicating



the change. Fortupately, because the time constant of many first-order instruments is small relative to the dynamics of the process being measured, no serious problems are created.

III Example 2.6

A balloon is equipped with temperature- and altitude-measuring instruments and has radio equipment that can transmit the output readings of these instruments back to the ground. The balloon is initially anchored to the ground with the instrument output readings in steady state. The altitude-measuring instrument is approximately zero order, and the temperature transducer is first order with a time constant of 15 seconds. The temperature on the ground, T_0 , is 10°C and the temperature T_n at an altitude of *x* meters is given by the relation: $T_n = T_0 - 0.01x$.

- (a) If the balloon is released at time zero, and thereafter rises upward at a velocity of 5 meters/second, draw a table showing the temperature and altitude measurements reported at intervals of 10 seconds over the first 50 seconds of travel. Show also in the table the error in each temperature reading.
- (b) What temperature does the balloon report at an altitude of 5000 meters?

Solution

In order to answer this question, it is assumed that the solution of a first-order differential equation has been presented to the reader in a mathematics course. If the reader is not so equipped, the following solution will be difficult to follow.

Let the temperature reported by the balloon at some general time t be T_r . Then T_a is related to T_r by the relation:

$$T_{r} = \frac{T_{s}}{1 + \tau D} = \frac{T_{o} - 0.01 x}{1 + \tau D} = \frac{10 - 0.01 x}{1 + 15 D}.$$

It is given that x = St, thus

$$T_r = \frac{10 - 0.05t}{1 + 15D}$$

The transient or complementary function part of the solution ($T_n = 0$) is given by $T_{n,p} = C e^{-\alpha/3}$

The particular integral part of the solution is given by $T_{r_{\mu}} = 10 - 0.05(t - 15)$ Thus, the whole solution is given by $T_r = T_{r_{\mu}} + T_{r_{\mu}} = Ce^{-\sqrt{15}} + 10 - 0.05(t - 15)$ Applying initial conditions: At t = 0, $T_r = 10$, that is, $10 = Ce^{-0} + 10 - 0.05(-15)$ Thus C = -0.75 and the solution can be written as $T_r = 10 - 0.75e^{-t/15} - 0.05(t - 15)$

Using the aforementioned expression to calculate *T*, for various values of *t*, the following rable can be constructed:

Time	Altitude	Temperature reading	Temperature error
0	0	10	0
10	50	9.86	0.36
20	100	9.55	0.55
30	150	9.15	0.65
40	200	8.70	0.70
40	250	8.22	0.72

(c) At 5000 m, t = 1000 seconds. Calculating T, from the aforementioned expression:

$$T_r = 10 - 0.75e^{-1000/15} - 0.05(1000 - 15).$$

The exponential term approximates to zero and so T, can be written as

 $T_r \approx 10 - 0.05(985) = -39.25^{\circ}C.$

This result might have been inferred from the table given earlier where it can be seen that the error is converging toward a value of 0.75. For large values of t, the transducer reading lags the true temperature value by a period of time equal to the time constant of 15 seconds. In this time, the balloon travels a distance of 75 meters and the temperature falls by 0.75°. Thus for large values of t, the output reading is always 0.75° less than it should be.

2.4.3 Second-Order Instrument

If all coefficients $a_3 \ldots a_n$ other than a_0, a_1 , and a_2 in Equation (2.2) are assumed zero, then we get

$$\sigma_2 \frac{d^2 q_a}{dt^2} + \sigma_1 \frac{dq_a}{dt} + \sigma_0 q_a = b_0 q_1. \tag{2.7}$$

Applying the D operator again:

 $a_2 D^2 q_a + a_1 D q_a + a_0 q_0 = b_0 q_0$

and scarcinging:

$$q_{\mu} = \frac{h_0 q_1}{a_0 + a_1 D + a_2 D^2}.$$
 (2.8)

It is convenient to recupsess the variables a_0, a_1, a_2 , and b_0 in Equation (2.8) in terms of three parameters: K (static consistivity), to (undamped natural frequency), and ξ (damping ratio), where

$$K = b_0/a_0$$
 ; $m = \sqrt{a_0/a_2}$; $\xi = a_1/2\sqrt{a_0a_2}$

E can be written as

$$\xi = \frac{a_1}{2a_0\sqrt{a_2/a_0}} = \frac{a_1\omega}{2a_0}$$

If Equation (2.8) is now divided through by a₀, we get

$$q_{\mu} = \frac{(b_{0}/a_{0})q_{i}}{1 + (a_{1}/a_{0})D + (a_{2}/a_{0})D^{2}}$$
(2.9)

The terms in Equation (2.9) can be written in terms of to and E as follows:

$$\frac{\mathbf{b}_{0}}{\mathbf{a}_{0}} = \mathbf{K} \qquad (\frac{\mathbf{a}_{1}}{\mathbf{a}_{0}}) \mathbf{D} = \frac{2\xi \mathbf{D}}{\mathbf{\omega}} \qquad ; \qquad (\frac{\mathbf{a}_{2}}{\mathbf{a}_{0}}) \mathbf{D}^{2} = \frac{\mathbf{D}^{2}}{\mathbf{\omega}^{2}}.$$

Hence, dividing Equation (2.9) through by a_1 and substituting for a_0 , a_1 , and a_2 gives

$$\frac{q_o}{q_i} = \frac{R}{D^2/\omega^2 + 2\xi D/\omega + 1}$$
(2.10)

This is the standard equation for a second-order system, and any instrument whose response can be described by it is known as a second-order instrument. If Equation (2.9) is solved analytically. the shape of the step response obtained depends on the value of the damping ratio parameter ξ . The output responses of a second-order instrument for various values of ξ following a step change in the value of the measured quantity at time *t* are shown in Figure 2.12. For case A, where $\xi = 0$, there is no damping and the instrument output exhibits constant amplitude oscillations when disturbed by any change in the physical quantity measured. For light damping of $\xi = 0.2$. represented by case B, the response to a step change in input is still oscillatory but the oscillations die down gradually. A further increase in the value of ξ reduces oscillations and overshorts still more, as shown by curves C and D, and finally the response becomes very overdamped, as shown by curve E, where the output reading croops up slowly toward the correct reading. Clearly, the extreme response curves A and E are grouply unmitable for any measuring instrument. If an instrument were to be only ever subjected to step inputs, then the design strategy would be to aim toward a damping ratio of 0.707, which gives the critically damped response (C). Unfortunately, most of the physical quantities that instruments are required to measure do not change in the mathematically convenient form of stops, but rather in the form of ramps of varying slopes. As the



Response characteristics of second-order instruments.

form of the input variable changes, so the best value for ξ varies, and choice of ξ becomes one of compromise between those values that are best for each type of input variable behavior insticupated. Commercial second-order instruments, of which the accelerometer is a common example, are generally designed to have a damping ratio (ξ) somewhere in the range of 0.6-0.8.

2.5 Necessity for Calibration

The foregoing discussion has described the static and dynamic characteristics of measuring instruments in some detail. However, an important qualification that has been omitted from this thecasion is that an instrument only conforms to stated static and dynamic patterns of behavior offer it has been calibrated. It can normally be assumed that a new instrument will have been calibrated when it is obtained from an instrument manufacturer and will therefore initially behave seconding to the characteristics stated in the specifications. During use, however, its behavior will pathally diverge from the stated specification for a variety of reasons. Such reasons include

mechanical wear and the effects of dirt, dust, fumes, and chemicals in the operating environment. The rate of divergence from standard specifications varies according to the type of instrument, the frequency of usage, and the severity of the operating conditions. However, there will come a time, determined by practical knowledge, when the characteristics of the instrument will have drifted from the standard specification by an unacceptable amount. When this situation is reached, it is necessary to recalibrate the instrument back to standard specifications. Such recalibration is performed by adjusting the instrument at each point in its output range until its output readiags are the same as those of a second standard instrument to which the same inputs are applied. This second instrument is one kept solely for calibration purposes whose specifications are accurately known. Calibration procedures are discussed more fully in Chapter 4.

2.6 Summary

This chapter began by reviewing various different classes of instruments and considering how these differences affect their typical usage. We saw, for example, that null-type instruments are favored for calibration duties because of their superior accuracy, whereas deflection-type instruments are easier to use for routine measurements. We also looked at the distinction between active and passive instruments, analogue and digital instruments, indicators and signal output-type instruments, and, finally, smart and nonsmart instruments. Following this, we went on to look at the various static characteristics of instruments. These define the quality of measurements when an instrument output has settled to a steady reading. Several important lessons arose out of this coverage. In particular, we saw the important distinction between accuracy and precision. which are often equated incorrectly as meaning the same thing. We saw that high precision does not promise anything at all about measurement accuracy; in fact, a high-precision instrument can sometimes give very poor measurement accuracy. The final topic covered in this chapter was the dynamic characteristics of instruments. We saw that there are three kinds of dynamic characteristics: zero order, first order, and second order. Analysis of these showed that both firstand second-order instruments take time to settle to a steady-state reading when the measured quantity changes. It is therefore necessary to wait until the dynamic motion has ended before a reading is recorded. This places a serious limitation on the use of first- and second-order instruments to make repeated measurements. Clearly, the frequency of repeated measurements is limited by the time taken by the instrument to settle to a steady-state reading.

2.7 Problems

2.1. Briefly explain four ways in which measuring instruments can be subdivided into different classes according to their mode of operation, giving examples of instruments that fall into each class. Instrument Types and Parformance Characteristics 35

- 2.2. Explain what is meant by
 - (a) active instruments(b) passive instruments

Give examples of each and discuss the relative merits of these two classes of instruments.

- 2.3. Discuss the advantages and disadvantages of null and deflection types of measuring instruments. What are null types of instruments mainly used for and why?
- 2.4. What are the differences between analogue and digital instruments? What advantages do digital instruments have over analogue ones?
- 2.5. Explain the difference between static and dynamic characteristics of measuring instruments.
- 2.6. Briefly define and explain all the static characteristics of measuring instruments.
- 2.7. How is the accuracy of an instrument usually defined? What is the difference between accuracy and precision?
- 2.8. Draw sketches to illustrate the dynamic characteristics of the following: (a) zero-order instrument
 - (b) first-order instrument
 - (c) second-order instrument

In the case of a second-order instrument, indicate the effect of different degrees of damping on the time response.

- 2.9. State briefly how the dynamic characteristics of an instrument affect its usage.
- 2.10. A tungsten resistance thermometer with a range of -270 to +1100 C has a quoted inaccuracy of ±1.5% of full-scale reading. What is the likely measurement error when it is reading a temperature of 950°C?
- 2.11. A batch of steel rods is manufactured to a nominal length of 5 meters with a quoted telerance of ± 2%. What is the longest and shortest length of rod to be expected in the batch?
- 2.12. What is the measurement range for a micrometer designed to measure diameters hoween 5.0 and 7.5 cm?
- 2.13. A tangsten/5th thenium-tangsten/26th thenium thermocouple has an output e.m.f. as shown in the following table when its hot (measuring) junction is at the temperatures mown. Determine the sensitivity of measurement for the thermocouple in mV/°C.

mV	4.37	8.74	13.11	17.48
°C	250	300	750	1080

2.14. Define consitivity drift and zero drift. What factors can cause consitivity drift and zero drift in instrument characteristics?

2.15. (a) An instrument is calibrated in an environment at a temperature of 20°C and the following output readings y are obtained for various input values x:

	13.1	26.3	39.3	52.4	65.5	78.6
έ.	5	10	15	20	25	30

Determine the measurement sensitivity, expressed as the ratio y/x.
(b) When the instrument is subsequently used in an environment at a temperature of 50°C, the input/output characteristic changes to the following:

14.7	29.4	44.1	58.8	73.5	88.2
5	10	15	20	25	30

Determine the new measurement sensitivity. Hence determine the sensitivity drift due to the change in ambient temperature of 30°C.

2.16. The following temperature measurements were taken with an infrared thermometer that produced biased measurements due to the instrument being out of calibration. Calculate the bias in the measurements.

	are measured by uncalibrated	
instrument ("C) Carroct value of temperature ("	instrument (°C)	Correct value of temperature (*C
20 21.5	20	21.5
35 36.5	35	36.5
50 51.5	50	51.5
65 66 5	65	66 5

2.17. A load cell is calibrated in an environment at a temperature of 21°C and has the following deflection/load characteristic:

Load (kg)	0	50	100	150	200
Deflection (mm)	0.0	1.0	2.0	3.0	4.0

When used in an environment at 35°C, its characteristic changes to the following:

Load (kg)	0	50	100	150	200
Deflection (mm)	0.2	1.3	2.4	3.5	4.6

(a) Determine the sensitivity at 21 and 35°C.

(b) Calculate the total zero drift and aensitivity drift at 35°C.

(c) Hence determine the zero drift and sensitivity drift coefficients (in units of µm/°C and (µm per kg)/(°C).

2.18. An unmanned submarine is equipped with temperature- and depth-measuring instruments and bas radio equipment that can transmit the output readings of these instruments back to the surface. The submarine is initially floating on the surface of the sea with the instrument output readings in steady state. The depth-measuring

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instrument is approximately zero order and the temperature transducer first order with a time constant of 50 seconds. The water temperature on the sea surface, T_0 is 20°C and the temperature T_n at a depth of x meters is given by the relation:

$$T_{\rm I} = T_0 - 0.01.$$

- (a) If the submarine starts diving at time zero, and thereafter goes down at a velocity of 0.5 meters/second, draw a table showing the temperature and depth measurements reported at intervals of 100 seconds over the first 500 seconds of travel. Show also in the table the error in each temperature reading.
- (b) What temperature does the submarine report at a depth of 1000 meters?
- 2.19. Write down the general differential equation describing the dynamic response of a second-order measuring instrument and state the expressions relating the static sonsitivity, undamped natural frequency, and damping ratio to the parameters in this differential equation. Sketch the instrument response for cases of heavy damping, critical damping, and light damping and state which of these is the usual target when a second-order instrument is being designed.
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3.1 Introduction

We have already been introduced to the subject of measurement uncertainty in the last chapter, in the context of defining the accuracy characteristic of a measuring instrument. The existence of measurement uncertainty means that we would be entirely wrong to assume (although the uninitiated might assume this) that the output of a measuring instrument or larger measurement system gives the exact value of the measured quantity. Measurement errors are impossible to avoid, although we can minimize their magnitude by good measurement system design accompanied by appropriate analysis and processing of measurement data.

We can divide errors in measurement systems into those that arise during the measurement process and those that arise due to later corruption of the measurement signal by induced noise during transfer of the signal from the point of measurement to some other point. This chapter considers only the first of these, with discussion on induced noise being deferred to Chapter 6.

It is extremely important in any measurement system to reduce errors to the minimum possible level and then to quantify the maximum remaining error that may exist in any instrument output reading. However, in many cases, there is a further complication that the final output from a measurement system is calculated by combining together two or more measurements of separate physical variables. In this case, special consideration must also be given to determining how the calculated error levels in each separate measurement should be combined to give the best estimate of the most fikely error magnitude in the calculated output quantity. This subject is considered in Section 3.7,

The starting point in the quest to reduce the incidence of errors arising during the measurement process is to carry out a detailed analysis of all error sources in the system. Each of these error sources can then be considered in turn, looking for ways of eliminating or at least reducing the magnitude of errors. Errors arising during the measurement process can be divided into two groups, known as systematic errors and random errors.

Systematic errors describe errors in the output readings of a measurement system that are consistently on one side of the correct reading, that is, either all errors are positive or are all negative. (Some books use alternative name bias errors for systematic errors, although this is not entirely incorrect, as systematic errors include errors such as sensitivity drift that are not biases.) Two major sources of systematic errors are system disturbance during measurement and the effect of environmental changes (sometimes known as modifying inputs), as discussed in Sections 3.4.1 and 3.4.2. Other sources of systematic error include bent meter needles, use of uncalibrated instruments, drift in instrument characteristics, and poor cabling practices. Even when systematic errors due to these factors have been reduced or eliminated, some errors remain that are inherent in the manufacture of an instrument. These are quantified by the accuracy value quoted in the published specifications contained in the instrument data shoet.

Random errors, which are also called precision errors in some books, are perturbations of the measurement either side of the true value caused by random and unpredictable effects, such that positive errors and negative errors occur in approximately equal numbers for a series of measurements made of the same quantity. Such perturbations are mainly small, but large perturbations occur from time to time, again unpredictably. Random errors often arise when measurements are taken by human observation of an analogue meter, especially where this involves interpolation between scale points. Electrical noise can also be a source of random errors. To a large extent, random errors can be overcome by taking the same measurement a number of times and extracting a value by averaging or other statistical techniques, as discussed in Section 3.5. However, any quantification of the measurement value and statement of error bounds remains a statistical quantity. Because of the nature of random errors and the fact that large perturbations in the measured quantity occur from time to time, the best that we can do is to express measurements in probabilistic terms: we may be able to assign a 95 or even 99% confidence level that the measurement is a certain value within error bounds of, say. \pm 1%, but we can never attach a 100% probability to measurement values that are subject to random errors. In other words, even if we say that the maximum error is $\leq \pm 0.5\%$ of the measurement roading, there is still a 1% chance that the error is greater than $\pm 0.5\%$.

Finally, a word must be said about the distinction between systematic and random errors. Error nources in the measurement system must be examined carefully to determine what type of error is present, systematic or random, and to apply the appropriate treatment. In the case of manual data measurements, a human observer may make a different observation at each attempt, but it is often reasonable to assume that the errors are random and that the must of these readings is likely to be close to the correct value. However, this is only true as long as the human observer is not introducing a parallax-induced systematic error as well by persistently reading the position of a needle against the scale of an analogue meter from one side rather than from directly above. A human-induced systematic error is also introduced if an instrument with a first-order characteristic is read before it has settled to its final reading. Wherever a systematic error exists alongside random errors, correction has to be made for the systematic error in the measurements before statistical techniques are applied to reduce the effect of random errors.

3.2 Sources of Systematic Error

The main sources of systematic error in the output of measuring instruments can be summarized as

- · effect of environmental disturbances, often called modifying inputs
- disturbance of the measured system by the act of measurement
- · changes in characteristics due to wear in instrument components over a period of time
- resistance of connecting leads

These various sources of systematic error, and ways in which the magnitude of the errors can be reduced, are discussed here.

3.2.1 System Disturbance due to Measurement

Disturbance of the measured system by the act of measurement is a common source of systematic error. If we were to start with a beaker of hot water and wished to measure its temperature with a mercury-in-glass thermometer, then we would take the thermometer, which would initially be at room temperature, and plunge it into the water. In so doing, we would be introducing a relatively cold mass (the thermometer) into the hot water and a heat transfer would take place between the water and the thermometer. This heat transfer would lower the temperature of the water. While the reduction in temperature in this case would be so small as to be undetectable by the limited measurement resolution of such a thermometer, the effect is finite and clearly establishes the principle that, in nearly all measurement situations, the process of measurement disturbs the system and alters the values of the physical quantities being measured.

A particularly important example of this occurs with the orifice plate. This is placed into a fluid-carrying pipe to measure the flow rate, which is a function of the pressure that is measured either side of the orifice plate. This measurement procedure causes a permanent pressure loss in the flowing fluid. The disturbance of the measured system can often be very significant.

Thus, as a general rule, the process of measurement always disturbs the system being measured. The magnitude of the disturbance varies from one measurement system to the next and is affected particularly by the type of instrument used for measurement. Ways of minimizing disturbance of measured systems are important considerations in instrument design. However, an accurate understanding of the mechanisms of system disturbance is a prerequisite for this.

Measurements in electric circuits

In analyzing system disturbance during measurements in electric circuits, Thévenin's theorem (see Appendix 2) is often of great assistance. For instance, consider the circuit shown in Figure 3.1a in which the voltage across resistor R_5 is to be measured by a voltmeter with resistance R_m . Here, R_m acts as a shunt resistance across R_5 , decreasing the resistance between points AB and so disturbing the circuit. Therefore, the voltage E_m measured by the meter is not the value of the voltage E_n that existed prior to measurement. The extent of the disturbance can be assessed by calculating the open-circuit voltage E_n and comparing it with E_m .

Thevenin's theorem allows the circuit of Figure 3.1s comprising two voltage sources and five resistors to be replaced by an equivalent circuit containing a single resistance and one







Figure 3.7

Analysis of circuit loading: (a) circuit in which the voltage across R_5 is to be measured, (b) equivalent circuit by Thévenin's theorem, and (c) circuit used to find the equivalent single.

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voltage source, as shown in Figure 3.1b. For the purpose of defining the equivalent single resistance of a circuit by Thevenis's theorem. all voltage sources are represented just by their internal resistance, which can be approximated to zero, as shown in Figure 3.1c. Analysis proceeds by calculating the equivalent resistances of sections of the circuit and building these up until the required equivalent resistance of the whole of the circuit is obtained. Starting at C and D, the circuit to the left of C and D coasists of a aeries pair of resistances (R_1 and R_2) in parallel with R_3 , and the equivalent resistance can be written as

$$\frac{1}{R_{CD}} = \frac{1}{R_1 + R_2} + \frac{1}{R_3} \quad \text{or} \quad R_{CD} = \frac{(R_1 + R_2)R_1}{R_1 + R_2 + R_3}$$

Moving now to A and B, the circuit to the left consists of a pair of series resistances (R_{CD} and R_4) in parallel with R_5 . The equivalent circuit resistance R_{AB} can thus be written as

$$\frac{1}{R_{AB}} = \frac{1}{R_{CD} + R_4} + \frac{1}{R_5} \quad \text{or} \quad R_{AB} = \frac{(R_4 + R_{CD})R_5}{R_4 + R_{CD} + R_5}$$

Substituting for R_{CD} using the expression derived previously, we obtain

$$R_{AB} = \frac{\left[\frac{(R_1 + R_2)R_3}{R_1 + R_2 + R_3} + R_4\right]R_5}{\frac{(R_1 + R_2)R_3}{R_1 + R_2 + R_3} + R_4 + R_5}.$$
(3.1)

Defining I as the current flowing in the circuit when the measuring instrument is connected to it, we can write

$$I = \frac{E_a}{R_{AB} + R_m},$$

and the voltage measured by the meter is then given by

$$E_{\rm m} = \frac{R_{\rm m}E_{\rm s}}{R_{\rm AB} + R_{\rm m}}$$

In the absence of the measuring instrument and its resistance R_m , the voltage across AB would be the equivalent circuit voltage source whose value is E_m . The effect of measurement is therefore to reduce the voltage across AB by the ratio given by

$$\frac{E_m}{E_\sigma} = \frac{R_m}{R_{AB} + R_m}.$$
(3.2)

It is thus obvious that as R_m gets larger, the ratio E_m/E_o gets closer to unity, showing that the design strategy should be to make R_m as high as possible to minimize disturbance of the

measured system. (Note that we did not calculate the value of E_{er} as this is not required in quantifying the effect of R_{m} .)

At this point, it is interesting to note the constraints that exist when practical attempts are made to achieve a high internal resistance in the design of a moving-coil voltmeter. Such an instrument consists of a coil carrying a pointer mounted in a fixed magnetic field. As current flows through the coil, the interaction between the field generated and the fixed field causes the pointer it carries to turn in proportion to the applied current (for further details, see Chapter 7). The simplest way of increasing the input impedance (the resistance) of the meter is either to increase the number of turns in the coil or to construct the same number of coil turns with a higher resistance material. However, either of these solutions decreases the current flowing is the coil, giving less magnetic torque and thus decreasing the measurement pensitivity of the instrument (i.e., for a given applied voltage, we get less deflection of the pointer). This problem can be overcome by changing the spring constant of the restraining aprings of the instrument, such that less torque is required to turn the pointer by a given amount. However, this reduces the ruggedness of the instrument and also demands better pivot design to reduce friction. This highlights a very important but tiresome principle in instrument design: any attempt to improve the performance of an instrument in one respect generally decreases the performance in some other aspect. This is an inescapable fact of life with passive instruments such as the type of voltmeter mentioned and is often the reason for the use of alternative active instruments such as digital voltmeters, where the inclusion of auxiliary power improves performance greatly.

Bridge circuits for measuring resistance values are a further example of the need for careful design of the measurement system. The impedance of the instrument measuring the bridge output voltage must be very large in comparison with the component resistances in the bridge circuit. Otherwise, the measuring instrument will load the circuit and draw current from it. This is discussed more fully in Chapter 9.

Example 3.1

Suppose that the components of the circuit shown in Figure 3.1a have the following values:

 $R_1 = 400 \Omega; R_2 = 600 \Omega; R_3 = 1000 \Omega; R_4 = 500 \Omega; R_5 = 1000 \Omega$

The voltage across AB is measured by a voltmeter whose internal resistance is 0.00 Ω . What is the measurement error caused by the resistance of the measuring instrument?

Solution

Proceeding by applying Thevenin's theorem to find an equivalent circuit to that of Figure 3.1a of the form shown in Figure 3.1b, and substituting the given component values into the equation for R_{AB} (3.1), we obtain

$$R_{\rm eff} = \frac{[(1000^2/2000) + 500]1000}{(1000^2/2000) + 500 + 1000} = \frac{1000^2}{2000} = 500 \,\Omega$$

From Equation (3.2), we have

$$\frac{E_m}{E_d} = \frac{R_m}{R_{AB} + R_m}$$

The measurement error is given by $(E_o - E_m)$:

$$E_{\sigma} - E_{\sigma} = E_{\sigma} \left(1 - \frac{R_{\sigma}}{R_{AB} + R_{\sigma}} \right).$$

Substituting in values:

$$E_t - E_n = E_r \left(1 - \frac{9500}{10,000}\right) = 0.95E_s$$

Thus, the error in the measured value is 5%.

3.2.2 Errors due to Environmental Inputs

An environmental input is defined as an apparently real input to a measurement system that is actually caused by a change in the environmental conditions surrounding the measurement system. The fact that the static and dynamic characteristics specified for measuring instruments are only valid for particular environmental conditions (e.g., of temperature and pressure) has already been discussed at considerable length in Chapter 2. These specified conditions must be reproduced as closely as possible during calibration exercises because, away from the specified calibration conditions, the characteristics of measuring instruments vary to some extent and cause measurement errors. The magnitude of this environment-induced variation is quantified by the two constants known as sensitivity drift and zero drift, both of which are generally included in the published specifications for an instrument. Such variations of environmental conditions away from the calibration conditions are sometimes described as *modifying inputs* to the measurement system because they modify the output of the system. When such modifying inputs are present, it is often difficult to determine how much of the output change in a measurement system is due to a change in the measured variable and how much to a change in environmental conditions. This is illustrated by the following example. Suppose we are given a small closed box and told that it may contain either a mouse or a rat. We are also told that the box weighs 0.1 kg when empty. If we put the box onto a bathroom the and observe a reading of 1.0 kg, this does not immediately tell as what is in the box because the mading may be due to one of three things:

- (a) a 0.9 kg rat in the box (real input)
- (b) an empty box with a 0.9 kg bias on the scale due to a temperature change (environmental input)
- (c) a 0.4 kg mouse in the box together with a 0.5 kg bias (real + environmental inputs)

Thus, the magnitude of any environmental input must be measured before the value of the measured quantity (the real input) can be determined from the output reading of an instrument.

In any general measurement situation, it is very difficult to avoid environmental inputs, as it is either impractical or impossible to control the environmental conditions surrounding the measurement system. System designers are therefore charged with the task of either reducing the measurement system. System designers are therefore charged with the task of either reducing the effects of environmental inputs and correcting for them in the instrument output reading. The incliniques used to deal with environmental inputs and minimize their effects on the final output measurement follow a number of routes as discussed later.

3.2.3 Wear in Instrument Components

Symmatic errors can frequently develop over a period of time because of wear in instrument components. Recalibration often provides a full solution to this problem.

3.2.4 Connecting Loads

In connecting together the components of a measurement system, a constron source of error is the failure to take proper account of the resistance of connecting leads (or pipes in the case of parameterizity or hydraulically actuated measurement systems). For instance, in typical applications of a resistance thermometer, it is common to find that the thermometer is teparated from other parts of the measurement system by perhaps 100 meters. The resistance of such a length of 20-gauge copper wire is 7 Ω , and there is a further complication that such wire has a temperature coefficient of 1 m Ω° C.

Therefore, careful consideration needs to be given to the choice of connecting leads. Not only these due to be of adequate cross section so that their resistance is minimized, but they should be serviced adequately if they are thought likely to be subject to electrical or magnetic fields that could enterwise cause induced noise. Where acreening is thought emential, then the routing of cables also needs careful planning. In one application in the suffer's personal experience

involving instrumentation of an electric-arc steelmaking furnace, acreened signal-carrying cables between transducers on the arc furnace and a control room at the side of the furnace were initially corrupted by high-amplitude 50-Hz noise. However, by changing the route of the cables between the transducers and the control room, the magnitude of this induced noise was reduced by a factor of about ten.

3.3 Reduction of Systematic Errors

The prerequisite for the reduction of systematic errors is a complete analysis of the measurement system that identifies all sources of error. Simple faults within a system, such as bent meter needles and poor cabling practices, can usually be rectified readily and inexpensively once they have been identified. However, other error sources require more detailed analysis and treatment. Various approaches to error reduction are considered next.

3.3.1 Caraful Instrument Design

Careful instrument design is the most useful weapon in the battle against environmental inputs by reducing the sensitivity of an instrument to environmental inputs to as low a level as possible. For instance, in the design of strain gauges, the element should be constructed from a material whose resistance has a very low temperature coefficient (i.e., the variation of the resistance with temperature is very small). However, errors due to the way in which an instrument is designed are not always easy to correct, and a choice often has to be made between the high cost of redesign and the alternative of accepting the reduced measurement accuracy if redesign is not undertaken.

3.3.2 Calibration

Instrument calibration is a very important consideration in measurement systems and therefore calibration procedures are considered in detail in Chapter 4. All instruments suffer drift in their characteristics, and the rate at which this happens depends on many factors, such as the environmental conditions in which instruments are used and the frequency of their use. Error due to an instrument being out of calibration is never zero, even immediately after the instrument has been calibrated, because there is always some inherent error in the reference instrument that a working instrument is calibrated against during the calibration exercise. Nevertheless, the error immediately after calibration is of low magnitude. The calibration error then grows steadily with the drift in instrument characteristics until the time of the next calibration. The maximum error that exists just before an instrument is recalibrated can therefore be made smaller by increasing the frequency of recalibration so that the amount of drift between calibrations is reduced.

3.3.3 Method of Opposing Inputs

The method of opposing inputs compensates for the effect of an environmental input in a method of opposing inputs compensates for the effect of an environmental input that cancels it out. One example of how this technique is applied is in the type of millivoltmeter shown in Figure 3.2. This consists of a coil suspended in a fixed magnetic field produced by a permanent magnet. When an unknown voltage is applied to the coil, the magnetic field due to the current interacts with the fixed field and causes the coil (and a pointer attached to the coil) to turn. If the coil ministance R_{coil} is sensitive to temperature, then any environmental input to the system in the form of a so after the pointer output reading. Compensation for this is made by introducing a magnetude but opposite in sign to that of the coil. Thus, in response to an increase in temperature.

3.3.4 High-Gam Foodback

The benefit of adding high-gain feedback to many measurement systems is illustrated by sumsidering the case of the voltage-measuring instrument whose block diagram is shown in Figure 3.3. In this system, unknown voltage E_i is applied to a motor of torque constant K_{an} and the induced torque turns a pointer against the restraining action of a spring with spring





Block diagram for voltage-measuring instrument.

constant K_i . The effect of environmental inputs on the motor and spring constants is represented by variables D_m and D_r . In the absence of environmental inputs, the displacement of the pointer X_r is given by $Xo = K_m K_m^2$. However, in the presence of environmental inputs, both K_m and K_r change, and the relationship between X_o and E_i can be affected greatly. Therefore, it becomes difficult or impossible to calculate E_i from the measured value of X_o . Consider now what happens if the system is converted into a high-gain, closed-loop one, as shown in Figure 3.4, by adding an amplifier of gain constant K_a and a feedback device with gain constant K_f . Assume also that the effect of environmental inputs on the values of K_a and K_f are represented by D_a and D_f . The feedback device feeds back a voltage E_o proportional to the pointer displacement X_o . This is compared with the unknown voltage E_i by a comparator and the error is amplified. Writing down the equations of the system, we have

$$E_{\sigma} = K_{f}X_{\sigma}; X_{\sigma} = (E_{f} - E_{\sigma})K_{\sigma}K_{\sigma}K_{\sigma} = (E_{f} - K_{f}X_{\sigma})K_{\sigma}K_{m}K_{f}$$

Thus

$$E_i K_{\sigma} K_{m} K_i = (1 + K_f K_{\sigma} K_m K_i) X_{\sigma}.$$





that is.

$$X_{*} = \frac{K_{*}K_{*}K_{*}}{1 + K_{i}K_{*}K_{*}K_{*}}E_{i}.$$
(3.3)

Because K_a is very large (it is a high-gain amplifier), $K_f \cdot K_a + K_m \cdot K_s >> 1$, and Equation (3.3) induces to

$$X_{\sigma} = E_i / K_f.$$

This is a highly important result because we have reduced the relationship between X_a and E_i to one that involves only K_f . The manifivity of the gain constants K_{ab} , K_{ab} , and K_a to the anvironmental inputs D_{ab} , D_{ab} , and D_a has thereby been rendered irrelevant, and we only have to be concerned with one environmental input, D_f . Conveniently, it is usually easy to design a fixedback device that is insensitive to environmental inputs; this is much easier than trying to make a motor or spring insensitive. Thus, high-gain feedback techniques are often a very affective way of reducing a measurement system's sensitivity to environmental inputs. However, one potential problem that must be mentioned is that there is a possibility that high-gain feedback will cause instability in the system. Therefore, any application of this method must include careful mustility analysis of the system.

3.3.5 Signal Filtering

One frequent problem in measurement systems is corruption of the output reading by periodic moise, often at a frequency of 50 Hz caused by pickup through the close proximity of the measurement system to apparatus or current-carrying cables operating on a mains supply. Periodic noise corruption at higher frequencies is also often introduced by mechanical oscillation or vibration within some component of a measurement system. The amplitude of all such noise components can be substantially attenuated by the inclusion of filtering of an appropriate form in the system, as discussed at greater length in Chapter 6. Band-stop filters can be especially useful where corruption is of one particular known frequency, or, more generally, low-pass filters are employed to attenuate all noise in the frequency range of 50 Hz and above. Measurement systems with a low-level output, such as a bridge circuit measuring a strain gauge resistance, are particularly prone to noise, and Figure 3.5 shows typical corruption of a bridge output by 50-Hz pickup. The beneficial effect of putting a simple passive RC low-pass ritter across the output is shown in Figure 3.5.

3.3.6 Manual Correction of Output Reading

In the case of errors that are due either to system disturbance during the sci of measurement or to environmental changes, a good measurement technician can substantially reduce errors at the output of a measurement system by calculating the effect of such systematic errors and



making appropriate correction to the instrument readings. This is not necessarily an easy task and requires all disturbances in the measurement system to be quantified. This procedure is carried out automatically by intelligent instruments.

3.3.7 Intelligent Instruments

Intelligent instruments contain extra sensors that measure the value of environmental inputs and automatically compensate the value of the output reading. They have the ability to deal very effectively with systematic errors in measurement systems, and errors can be attenuated to very low levels in many cases. A more detailed coverage of intelligent instruments can be found in Chapter 11.

3.4 Quantification of Systematic Errors

Once all practical steps have been taken to eliminate or reduce the magnitude of systematic errors, the final action required is to estimate the maximum remaining error that may exist in a measurement due to systematic errors. This quantification of the maximum likely systematic error in a measurement requires careful analysis.

3.4.1 Quantification of Individual Systematic Error Components

The first complication in the quantification of systematic errors is that it is not usually possible to specify an exact value for a component of systematic error, and the quantification has to be in terms of a "best estimate." Once systematic errors have been reduced as far as measurably possible using the techniques explained in Section 3.3, a sensible approach to astimate the various kinds of remaining systematic error would be as follows.

Emironmental condition errors

If a measurement is subject to unpredictable environmental conditions, the usual course of action is to assume midpoint environmental conditions and specify the maximum measurement error as $\pm \pi$ % of the output reading to allow for the maximum expected deviation in environmental conditions away from this midpoint. Of course, this only refers to the case where the environmental conditions remain essentially constant during a period of measurement but vary unpredictably on perhaps a daily basis. If random fluctuations occur over a short period of time from causes such as random draughts of hot or cold air, this is a random error rather than a systematic error that has to be quantified according to the techniques explained in Section 3.5.

Colibration proves

All measuring instruments suffer from drift in their characteristics over a period of time. The schedule for recalibration is set so that the frequency at which an instrument is calibrated measus that the drift in characteristics by the time just before the instrument is due for recalibration is kept within an acceptable limit. The maximum error just before the instrument is due for recalibration becomes the basis for estimating the maximum likely error. This error due to the instrument being out of calibration is usually in the form of a bias. The best way to express this is to assume some midpoint value of calibration error and compensate all measurements by this midpoint error. The maximum measurement error over the full period of time between when the lastrument has just been calibrated and time just before the next calibration is due can then be aspressed as $\pm x\%$ of the output reading.

Example 3.2

The result branch frequency of a pressure transducer with a range of 0 to 10 bar is set an that is recalibrated once the measurement error has grown to $\pm 1\%$ of the full-scale resulting. Here, can its inaccuracy be expressed in the form of a $\pm 3\%$ error in the output resulting.

Solution

Just before the instrument is due for recalibration, the measurement error will have grown to ± 0.1 bar (1% of 10 bar). An amount of half this maximum error, that is, 0.05 bar, should be subtracted from all measurements. Having done this, the error just after the instrument has been calibrated will be -0.05 bar (-0.5% of full-scale reading) and the error just before the next recalibration will be ± 0.05 bar ($\pm 0.5\%$ of full-scale reading). Inaccuracy due to calibration error can then be bepressed as $\pm 0.05\%$ of full-scale reading.

System disturbance errors

Disturbance of the measured system by the act of measurement itself introduces a systematic error that can be quantified for any given set of measurement conditions. However, if the quantity being measured and/or the conditions of measurement can vary, the best approach is to calculate the maximum likely error under worst-case system loading and then to express the likely error as a plus or minus value of half this calculated maximum error, as suggested for calibration errors.

Measurement system leading errors

These have a similar effect to system disturbance errors and are expressed in the form of $\pm x\%$ of the output reading, where x is half the magnitude of the maximum predicted error under the most adverse loading conditions expected.

3.4.2 Calculation of Overall Systematic Error

The second complication in the analysis to quantify systematic errors in a measurement system is the fact that the total systemic error in a measurement is often composed of several separate components, for example, measurement system loading, environmental factors, and calibration errors. A worst-case prediction of maximum error would be to simply add up each separate systematic error. For example, if there are three components of systematic error with a magnitude of $\pm 1\%$ each, a worst-case prediction error would be the sum of the separate errors, that is, $\pm 3\%$. However, it is very unlikely that all components of error would be at their maximum or minimum values simultaneously. The usual course of action is therefore to combine separate sources of systematic error using a *root-sum-squares method*. Applying this method for a systematic component errors of magnitude $\pm 1\%, \pm x_3\%, \pm x_3\%, \dots \pm x_n\%$, the best prediction of likely maximum systematic error by the root-sum-squares method is

$$error=\pm\sqrt{x_1^2+x_2^2+x_3^2+\cdots+x_n^2}$$

Before closing this discussion on quantifying systematic errors, a word of warning must be given about the use of manufacturers' data sheets. When instrument manufacturers provide data sheets with an instrument that they have made, the measurement uncertainty or inaccuricy value quoted in the data sheets is the best estimate that the manufacturer can give about the way that the instrument will perform when it is new, used under specified conditions, and mealibrated at the recommended frequency. Therefore, this can only be a starting point m estimating the measurement accuracy that will be achieved when the instrument is actually used. Many sources of systematic error may apply in a particular measurement situation that are not included in the accuracy calculation in the manufacturer's data sheet, and careful mentification and analysis of all systematic errors are necessary, as described earlier.

Example 3.3

Three separate sources of systematic error are identified in a measurement system and, after reducing the magnitude of these errors as much as possible, the magnitudes of the three errors are estimated to be

System loading: ± 1.2% Environmental changes: 0.8% Calibration error: 0.5%

Calculate the maximum possible total systematic error and the likely system error by the root-mean-square method.

Solution

The maximum possible system error is $\pm (1.2 + 0.8 + 0.5)\% = \pm 2.5\%$

Applying the root-mean-square method,

likely error = $\pm \sqrt{1.2^2 + 0.8^2 + 0.5^2} = \pm 1.53\%$

3.5 Sources and Treatment of Random Errors

Random errors in measurements are caused by unpredictable variations in the measurement system. In some books, they are known by the alternative name precision errors. Typical sources of random error are

- measurements taken by human observation of an analogue meter, especially where this involves interpolation between scale points.
 - electrical noise.

 - rendom environmental changes, for example, sudden draught of nir.

Random errors are usually observed as small perturbations of the measurement either side of the correct value, that is, positive errors and negative errors occur in approximately equal numbers for a series of measurements made of the same constant quantity. Therefore, random errors can largely be eliminated by calculating the average of a number of repeated measurements. Of course, this is only possible if the quantity being measured remains at a constant value during the repeated measurements. This averaging process of repeated measurements can be done automatically by intelligent instruments, as discussed in Chapter 11.

While the process of averaging over a large number of measurements reduces the magnitude of random errors substantially, it would be entirely incorrect to assume that this totally eliminates random errors. This is because the mean of a number of measurements would only be equal to the correct value of the measured quantity if the measurement set contained an infinite number of values. In practice, it is impossible to take an infinite number of measurements. Therefore, in any practical situation, the process of averaging over a finite number of measurements only reduces the magnitude of random error to a small (but nonzero) value. The degree of confidence that the calculated mean value is close to the correct value of the measured quantity can be indicated by calculating the standard deviation or variance of data, these being parameters that describe how the measurements are distributed about the mean value (see Sections 3.6.1 and 3.6.2). This leads to a more formal quantification of this degree of confidence in terms of the standard error of the mean in Section 3.6.6.

3.6 Statistical Analysis of Measurements Subject to Random Errors

3.6.1 Maan and Median Values

The average value of a set of measurements of a constant quantity can be expressed as either the mean value or the median value. Historically, the median value was easier for a computer to compute than the mean value because the median computation involves a series of logic operations, whereas the mean computation requires addition and division. Many years ago, a computer performed logic operations much faster than arithmetic operations, and there were computational speed advantages in calculating average values by computing the median rather than the mean. However, computer power increased rapidly to a point where this advantage disappeared many years ago.

As the number of measurements increases, the difference between mean and median values becomes very small. However, the average calculated in terms of the mean value is always slightly closer to the correct value of the measured quantity than the average calculated as the median value for any finite set of measurements. Given the loss of any computational speed advantage because of the measure power of modern-day computers, this means that there is now little argument for calculating average values in terms of the median.

For any set of a measurements $x_1, x_2 \cdots x_n$ of a constant quantity, the most likely true value is the mean given by

$$x_{mres} = \frac{x_1 + x_2 + \cdots + x_n}{n},$$
 (3.4)

This is valid for all data sets where the measurement errors are distributed equally about the zero error value, that is, where positive errors are balanced in quantity and magnitude by magnitude errors.

The median is an approximation to the mean that can be written down without having to sum the measurements. The median is the middle value when measurements in the data sat are written down in ascending order of magnitude. For a set of a measurements $x_1, x_2 \cdots x_n$ of a constant quantity, written down in ascending order of magnitude, the median value is given by

$$x_{mulan} = x_{n+1/2}$$
 (3.5)

Thus, for a set of nine measurements $x_1, x_2 \cdots x_n$ arranged in order of magnitude, the median value is x_3 . For an even number of measurements, the median value is midway between the two center values, that is, for 10 measurements $x_1 \cdots x_{100}$, the median value is given by $(x_5 + x_6)/2$.

Suppose that the length of a steel bar is measured by a number of different observers and the following set of 11 measurements are recorded (units millimeter). We will call this measurement set A.

Using Equations (3.4) and (3.5), mean = 409.0 and median = 408. Suppose now that the measurements are taken again using a better measuring rule and with the observers taking more care to produce the following measurement set B:

409 406 402 407 405 404 407 404 407 407 408 (Measurement set B)

For these measurements, mean = 406.0 and median = 407. Which of the two measurement sets, A and B, and the corresponding mean and median values should we have the most comfidence in? Intuitively, we can regard measurement set B as being more reliable because the measurements are much closer together. In set A, the spread between the smallest (396) and largest (430) value is 34, while in set B, the spread is only 6.

Thus, the smaller the spread of the measurements, the more confidence we have in the mean or median value calculated.

Let us now see what happens if we increase the number of measurements by extending measurement set B to 23 measurements. We will call this measurement set C.

409 406 402 407 405 404 407 404 407 407 408 406 410 406 405 408 406 409 406 405 409 406 407

(Measurement set C)

Now, mean = 406.5 and median = 406

This confirms our earlier statement that the median value tends toward the mean value as the number of measurements increases.

3.6.2 Standard Deviation and Variance

Expressing the spread of measurements simply as a range between the largest and the smallest value is not, in fact, a very good way of examining how measurement values are distributed about the mean value. A much better way of expressing the distribution is to calculate the variance or standard deviation of the measurements. The starting point for calculating these parameters is to calculate the deviation (error) d_i of each measurement x_i from the mean value x_{max} in a set of measurements x_1, x_2, \dots, x_n :

$$d_i = x_i - x_{mean}.$$
 (5.0)

The variance (V_0) of the set of measurements is defined formally as the mean of the squares of deviations:

$$V_{s} = \frac{d_{1}^{2} + d_{2}^{2} \cdots d_{n}^{2}}{n}.$$
 (3.7)

The standard deviation (G,) of the set of measurements is defined as the square root of the variance:

$$\sigma = \sqrt{\nabla_n} = \sqrt{\frac{d_1^2 + d_2^2 \cdots d_n^2}{n}},$$
(3.8)

Unfortunately, these formal definitions for the variance and standard deviation of data are made with respect to an infinite population of data values whereas, in all practical situations, we can only have a finite set of measurements. We have made the observation previously that the mean value x_m of a finite set of measurements will differ from the true mean μ of the theoretical infinite population of measurements that the finite set is part of. This means that there is an error in the mean value x_m used in the calculation of d, in Equation (3.6), Because of this, Equations (3.7) and (3.8) give a biased estimate that tends to underestimate the variance and standard deviation of the infinite set of measurements. A better prediction of the variance of the infinite population can be obtained by applying the Bessel correction factor (n/n - 1) to the formula for V_n in Equation (3.7);

$$V = \left(\frac{n}{n-1}\right)V_{s} = \frac{d_{1}^{2} + d_{2}^{2} \cdots d_{n}^{2}}{n-1},$$
 (3.9)

where V_s is the variance of the finite set of measurements and V is the variance of the infinite population of measurements.

This leads to a similar better prediction of the standard deviation by taking the square rost of the square in Equation (3.9):

 $\sigma = \sqrt{V} = \sqrt{\frac{d_1^2 + d_2^2 \cdots d_n^2}{n-1}}$ (3.10)

Example 3.4

(4

Enculate of and V for measurement sets A, B, and C given earlier.

Solution

First, draw a table of measurements and deviations for set A (mean = 409 as inscutated earlier):

Meximitement	396	-420	594	416	404	405	400	420	396	413	430
Oesiaraan	-11	+11	-15	+7	-5	-1	-9	+11	-13	+4	+21
from mean											
(deviations)	121	121	225	49	25	1	81	121	169	16	441

 $\sum (demations^2) = 1370; n = number of measurements = 11.$

Then, from Equations (3.9) and (3.10), $V = \sum (deviations^2)/n - 1 = 1370/10 = 137$; $\sigma = \sqrt{V} = 11.7$.

Measurements and deviations for set B are (mean - 406 as calculated earlier):

Measurement	409	406	402	407	405	404	407	404	407	407	
Deviation	+3	0	-4	+1	-1	- 2	+1	-2	+1	+1	+2
(deviations) ²	9	0	16	1	1	4	1	4	1	1	

From these data, using Equations (3.9) and (3.10), V = 4.2 and $\sigma = 2.05$.

Brements and deviations for set C are (mean = 406.5 as calculated aarlier)

Deviation	409	406	402	407	405	404	407	404	407	407	+ 1.5
Deviation	+ 2.5	- 0.5	- 4.1	5 + 0.5	- 1.5	- 2.5	+ 0.5	- 2.5	+ 0.5	+ 0.5	
eviations) ²	6.25	0.25	20.2	5 0.25	2.25	6.25	0.25	6.25	0.25	0.25	2.25
Destation	406	410	406	405 4	06 40	6 40 <u>9</u>	406	405	409	406	407
	- 0.5	+ 3.5	- 0.5		1.5 -0).5 + 2.	5 - 0.5	5 - 1.5	5 + 2.5	- 0.5	- 0.5
levebons) ²	0.25	12.25	0.25	2.25 2	.25 0.2	15 6.2	5 0.25	2.25	6.25	0.25	0.25

From this data, using Equations (3.9) and (3.10), V = 3.53 and $\sigma = 1.88$.

Note that the smaller values of V and σ for measurement set B compared with A correspond with the respective size of the spread in the range between maximum and minimum values for the two sets.

- Thus, as V and a decrease for a measurement set, we are able to express greater confidence that the calculated mean or median value is close to the true value, that is, that the averaging process has reduced the random error value close to zero.
- Comparing V and σ for measurement sets B and C, V and σ get smaller as the number of measurements increases, confirming that confidence in the mean value increases as the number of measurements increases.

We have observed so far that random errors can be reduced by taking the average (mean or median) of a number of measurements. However, although the mean or median value is close to the true value, it would only become exactly equal to the true value if we could average an infinite number of measurements. As we can only make a finite number of measurements in a practical situation, the average value will still have some error. This error can be quantified as the *standard error of the mean*, which is discussed in detail a little later. However, before that, the subject of graphical analysis of random measurement errors needs to be covered.

3.6.3 Graphical Data Analysis Tachniques -- Frequency Distributions

Graphical techniques are a very useful way of analyzing the way in which random measurement errors are distributed. The simplest way of doing this is to draw a histogram. in which bands of equal width across the range of measurement values are defined and the number of measurements within each band is counted. The bands are often given the name data bins. A useful rule for defining the number of bands (bins) is known as the Sturgis rule, which calculates the number of bands as

Number of bands = $1 + 3.3 \log_{10}(n)$.

where n is the number of measurement values.

Example 3.5

Draw a histogram for the 23 measurements in set C of length measurement data given in Section 3.5, 1.

Solution

ther 23 measurements, the recommended number of bands calculated according to the Surger rule is $1 + 3.3 \log 10(23) = 5.49$. This rounds to five, as the number of bands must be an integer number

To come the span of measurements in data set C with five bands, data bands need to be 2 mm. The boundaries of these bands must be chosen carefully so that no measurements full on the boundary between different bands and cause ambiguity about which band to put them in. Because the measurements are integer numbers, this can be accomplished easily be defining the range of the first band as 401.5 to 403.5 and so on. A histogram can now be drawn as in Figure 3.6 by counting the number of measurements in each band.

In the first band from 401.5 to 403.5, there is just one measurement, so the height of the histogram in this band is 1 unit.

In the next band from 403.5 to 405.5, there are five measurements, so the height of the himogram in this band is 1 = 5 units.

The rest of the histogram is completed in a similar fashion.

When a histogram is drawn using a sufficiently large number of measurements, it will have the characteristic shape shown by truly random data, with symmetry about the mean value of the measurements. However, for a relatively small number of mean value, only approximate symmetry in the histogram can be expected about the mean value. It is a matter of judgment as to whether the shape of a histogram is close mough to symmetry to justify a conclusion that data on which it is based are truly





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random. It should be noted that the 23 measurements used to draw the histogram in Figure 3.6 were chosen carefully to produce a symmetrical histogram but exact symmetry would not normally be expected for a measurement data set as small as 23.

As it is the actual value of measurement error that is usually of most concern, it is often more useful to draw a histogram of deviations of measurements from the mean value rather than to draw a histogram of the measurements themselves. The starting point for this is to calculate the deviation of each measurement away from the calculated mean value. Then a *histogram of deviations* can be drawn by defining deviation bands of equal width and counting the number of deviation values in each band. This histogram has exactly the same shape as the histogram of raw measurements except that scaling of the horizontal axis has to be redefined in terms of the deviation values (these units are shown in parentheses in Figure 3.6).

Let us now explore what happens to the histogram of deviations as the number of measurements increases. As the number of measurements increases, smaller bands can be defined for the histogram, which retains its basic shape but then consists of a larger number of smaller steps on each side of the peak. In the limit, as the number of measurements approaches infinity, the histogram becomes a smooth curve known as a *frequency distribution curve*, as shown in Figure 3.7. The ordinate of this curve is the frequency of occurrence of each deviation value, F(D), and the abscissa is the magnitude of deviation, D.

The symmetry of Figures 3.6 and 3.7 about the zero deviation value is very useful for showing graphically that measurement data only have random errors. Although these figures cannot be used to quantify the magnitude and distribution of the errors



easily, very similar graphical techniques do achieve this. If the height of the frequency distribution curve is normalized such that the area under it is unity, then the curve in this form is known as a probability curve, and the height F(D) at any particular deviation magnitude D is known as the probability density function (p.d.f.). The condition that the area under the curve is unity can be expressed mathematically as



The probability that the error in any one particular measurement lies between two levels D_1 and D_2 can be calculated by measuring the area under the curve contained between two vertical lines drawn through D_1 and D_2 , as shown by the right-hand hatched area in Figure 3.7. This can be expressed mathematically as

$$P(D_1 \le D \le D_2) = \int_{D_1} F(D) dD$$
 (3.11)

Of particular importance for assessing the maximum error likely in any one measurement is the *cumulative distribution function* (c.d.f.). This is defined as the probability of observing a value less than or equal to D_o and is expressed mathematically as

$$\mathcal{P}(\mathbf{D} \le \mathbf{D}_0) = \int_{-\infty}^{\mathbf{D}_0} \mathcal{F}(\mathbf{D}) d\mathbf{D} \tag{3.12}$$

Thus, the c.d.f. is the area under the curve to the left of a vertical line drawn through D_p at shown by the left-hand hatched area in Figure 3.7.

The deviation magnitude D_p corresponding with the peak of the frequency distribution cares (Figure 3.7) is the value of deviation that has the greatest probability. If the errors are entirely random in nature, then the value of D_p will equal zero. Any nonzero value of D_p indicates systematic errors in data in the form of a bias that is often removable by recalibration.

3.6.4 Gaussian (Normal) Distribution

Measurement sets that only contain random errors usually conform to a distribution with a particular shape that is called *Gaussian*, although this conformance must always be leated (see the later section headed "Goodness of fit"). The shape of a Gaussian curve is such that the impressive of small deviations from the meas value is much greater than the frequency of large deviations. This coincides with the usual expectation in measurements subject to random errors.

that the number of measurements with a small error is much larger than the number of measurements with a large error. Alternative names for the Gaussian distribution are normal distribution or bell-shaped distribution. A Gaussian curve is defined formally as a normalized frequency distribution that is symmetrical about the line of zero error and in which the frequency and magnitude of quantities are related by the expression:

$$F(x) = \frac{1}{\sigma\sqrt{2\pi}} e^{\left[-(s-m)^2/2\sigma^2\right]},$$
 (3.13)

where *m* is the mean value of data set *x* and the other quantities are as defined before. Equation (3.13) is particularly useful for analyzing a Gaussian set of measurements and predicting how many measurements lie within some particular defined range. If measurement deviations *D* are calculated for all measurements such that D = x - m, then the curve of deviation frequency F(D) plotted against deviation magnitude *D* is a Gaussian curve known as the error frequency distribution curve. The mathematical relationship between F(D) and *D* can then be derived by modifying Equation (3.13) to give

$$F(D) = \frac{1}{\sigma \sqrt{2\pi}} e^{[-D^2/2\sigma^2]},$$
 (3.14)

The shape of a Gaussian curve is influenced strongly by the value of σ , with the width of the curve decreasing as σ becomes smaller. As a smaller σ corresponds with typical deviations of measurements from the mean value becoming smaller, this confirms the earlier observation that the mean value of a set of measurements gets closer to the true value as σ decreases.

If the standard deviation is used as a unit of error, the Gaussian curve can be used to determine the probability that the deviation in any particular measurement in a Gaussian data set is greater than a certain value. By substituting the expression for F(D) in Equation (3.14) into probability Equation (3.11), the probability that the error lies in a band between error levels D_1 and D_2 can be expressed as

$$P(D_1 \le D \le D_2) = \int_{D_1}^{D_2} \frac{1}{\sqrt{2\pi}} e^{\left(-D^2/2\sigma^2\right)} dD.$$
(3.15)

Solution of this expression is simplified by the substitution

$$= D/\sigma. \tag{3.16}$$

The effect of this is to change the error distribution curve into a new Gaussian distribution that has a standard deviation of one ($\sigma = 1$) and a mean of zero. This new form, shown in Figure 3.8, is known as a *standard Gaussian curve* (or sometimes as a *z distribution*), and the dependent variable is now *z* instead of *D*. Equation (3.15) can now be re-expressed as



Figure 3.8 Standard Gaussian curve [F(z) versus z].

$$P(D_1 \le D \le D_2) = P(z_1 \le z \le z_2) = \int_{z_1}^{z_2} \frac{1}{\sigma \sqrt{2\pi}} e^{\left(-c^2/2\right)} dz.$$
(3.17)

Unfortunately, neither Equation (3.15) nor Equation (3.17) can be solved analytically using tables of standard integrals, and numerical integration provides the only method of solution. However, in practice, the tedium of numerical integration can be avoided when analyzing data because the standard form of Equation (3.17), and its independence from the particular values of the mean and standard deviation of data, means that standard Gaussian tables that tabulate F(z) for various values of z can be used.

3.6.5 Standard Gaussian Tables (z Distribution)

A standard Gaussian table (sometimes called z distribution), such as that shown in Table 3.1, tabulates the area under the Gaussian curve F(z) for various values of z, where F(z) is given by

$$F(z) = \int_{-\infty}^{\infty} \frac{1}{\sigma\sqrt{2\pi}} e^{(-z^2/2)} dz.$$
 (3.18)

Thus, for gives the proportion of data values that are less than or equal to z. This proportion is the area under the curve of F(z) against z that is to the left of z. Therefore, the expression given in Equation (3.17) has to be evaluated as $[F(z_2) - F(z_1)]$. Study of Table 3.1 shows that F(z) = 0.5 for z = 0. This confirms that, as expected, the number of data values ≤ 0 is 50% of the total. This must be so if data only have random errors. It will also be observed that Table 3.1, in common with most published standard Gaussian tables, only gives F(z) for

	Table 3.1	Error Fu	Inction T	able (Are	n under	a Gausai	an Cerve	or z Dis	tribution)
2	0.00	0.01	0.02	0.03	0.04	0.05	9.96	0.07	0.06	0.09
0.0	0.5000	0.5000	0.5080	0.5120	0.5160	0.5199	0.5239	0.5279	0.5319	0 5359
0.1	0.5398	0.5438	0.5478	0.5517	0.5557	0.5596	0.5636	0.5675	0.5714	0.5753
0.2	0.5793	0.5832	0.5871	0_5910	0.5948	0.5987	0.6026	0.6064	0.6103	0.6141
0.3	0.6179	0.6217	0.6255	0.6293	0.6331	0.6368	0.6406	0.6443	0.6480	0.6517
0.4	0.6554	0.6591	0.6628	0.6664	0.6700	0.6736	0.6772	0.6808	0.6844	0.6879
0.5	0.6915	0 69 50	0.6985	0.7019	0.7054	0.7088	0.7123	0.7157	0.7190	0.7224
0.6	0.7257	0,7291	0.7324	0 7357	0 7389	0.7422	0.7454	0.7486	0.7517	0.7549
0.7	0.7580	0.7611	0.7642	0.7673	0.7703	0 7734	0.7764	0.7793	0.7823	0.7852
0.8	0.7881	0.7910	0.7939	0_7967	0.7995	0.8023	0.8051	0.8078	0.8106	0.8133
0.9	0.8159	0.8186	0.8212	0.8238	0.8264	0.8289	0.8315	0.8340	0.8365	0 8389
1.0	0.8413	0.8438	0.8461	0.8485	0.8506	0.8531	0.8554	0.8577	0.8599	0.8621
1.1	0.8643	0.8665	0.8686	0.8708	0.8729	0.8749	0.8770	0.8790	0.8810	0.8830
1.2	0.8849	0.8669	0.8888	0.8906	0.8925	0.8943	0.8962	0.8980	0.8997	0.9015
1.3	0.9032	0.9049	0.9066	0.9082	0 9099	0.9115	09131	0 9147	0.9162	0.9177
1.4	0.9192	0 9207	0.9222	0.9236	0.9251	0.9265	0.9279	0.9292	0.9306	0.9319
1.5	0.9332	0.9345	0.9357	0.9370	0.9382	0.9394	0.9406	0.9418	0.9429	0.9441
1.6	0.9452	0.9463	0.9474	0.9484	0.9495	0.9505	0.9515	0.9525	0.9535	0.9545
1.7	0.9554	0.9564	0.9573	0.9582	0.9591	0.9599	0.9608	0.9616	0.9625	0.9633
1.8	0.9641	0.9648	0.9656	0.9664	0.9671	0.9678	0.9686	0.9693	0.9699	0.9706
1.9	0.9713	0.9719	0.9726	0.9732	0.9738	0.9744	0.9750	0.9756	0.9761	0.9767
2.0	0.9772	0.9778	0.9783	0.9788	0.9793	0.9798	0.9803	0 9808	0.9812	0.9817
2.1	0 9821	0 9826	0.9830	0.9834	0.9838	0 9842	0 9846	0.9650	0.9854	0 9857
2.2	0.9861	0.9864	0.9868	0.9871	0.9875	0.9878	0.9581	0.9884	0 9887	0.9890
2.3	0.9893	0.9896	0.9896	0.9901	0.9904	0 9906	0.9909	0.9911	0.9913	0.9916
2.4	0.9918	0.9920	0.9922	0.9924	0.9926	0.9928	0.9930	0.9932	0.9934	0 9936
2.5	0.9938	0_9940	0.9941	0_9943	0.9945	0.9946	0.9948	0.9949	0.9951	0.9952
2.6	0.9953	0.9955	0.9956	0.9957	0.9959	0.9960	0.9961	0.9962	0.9963	0.9964
2.7	0.9965	0.9966	0.9967	0.9968	0_9969	0.9970	0.9971	0.9972	0.9973	0.9974
2.8	0.9974	0.9975	0.9976	0.9977	0.9977	0.9978	0.9979	0 9979	0.9980	0 9981
2.9	0.9981	0.9982	0.9982	0.9943	0.9984	0.9984	0.9985	0 9985	0 9986	0 9986
3.0	0.9986	0.9987	0.9987	0.9988	0.9968	0.9989	0 9989	0 9989	0 9990	0 9990
3.1	0 9990	0 9991	0.9991	0.9991	0.9992	D.9992	0.9992	0 9992	0.9993	0 9993
3.2	0.9993	0.9993	0.9994	0.9994	0.9994	0.9994	0.9994	0.9995	0.9995	0.9995
3.3	0.9995	0.9995	0.9995	0.9996	0.9996	0.9996	0.9996	0.9996	0.9996	0.9996
3.4	0.9997	0.9997	0.9997	0.9997	0.9997	0.9997	0.9997	0.9997	0.9997	0.9998
3.5	0.9998	0.9998	0.9996	0.9998	0.9998	0.9998	0.9998	0 9998	0.9998	0 9998
3.6	0.9998	0 9998	0.9996	0.9999	0.9999	0.9999	0.9999	0 9999	0.9999	0.9999

positive values of z. For negative values of z, we can make use of the following relationship because the frequency distribution curve is normalized:

$$F(-z) = 1 - F(z). \tag{3.19}$$

[F(-z) is the area under the curve to the left of (-z), i.e., it represents the proportion of data values $\leq -z$.]

Example 3.6

How many measurements in a data set subject to random errors lie outside deviation boundaries of $+\sigma$ and $-\sigma$, that is, how many measurements have a deviation greater than

III Solution

The required number is represented by the sum of the two shaded areas in Figure 3.9, This can be expressed mathematically as $P(E < -\sigma \text{ or } E > +\sigma) = P(E < -\sigma) + P(E > +\sigma)$. For $E = -\sigma$, z = -1.0 [from Equation (3.14)].

Using Table 3.1: $P(E < -\sigma) = F(-1) = 1 - F(1) = 1 - 0.8413 = 0.1587$.

Similarly, for $E = +\sigma$, z = +1.0. Table 3.1 gives $P(E > +\sigma) = 1 - P(E < +\sigma) = 1 - P(1) = 1 - 0.8413 = 0.1587$. (This last step is valid because the frequency distribution curve is normalized such that the total area under it is unity.) Thus, $P[E < -\sigma] + P[E > +\sigma] = 0.1587 + 0.1587 = 0.3174 \sim 32\%$, that is, 32% of the measurements lie outside the $\pm \sigma$ boundaries, then 68% of the measurements lie inside.

The analysis just given shows that, for Gaussian-distributed data values, 68% of the measurements have deviations that lie within the bounds of $\pm \sigma$. Similar analysis shows that boundaries of $\pm 2\sigma$ contain 95.4% of data points, and extending the boundaries to $\pm 3\sigma$ encompasses 99.7% of data points. The probability of any data point lying outside particular deviation boundaries can therefore be expressed by the following table.



± a boundaries.

	Onviation Insundaries	% of data paints within boundary	Probability of any particular data pains being mittide boundary
	±0.	AB.0	32.0%
	±20	95.4	4.6%
	230	99.7	0.3%
1			

3.6.6 Standard Error of the Mean

The foregoing analysis has examined the way in which measurements with random errors are distributed about the mean value. However, we have already observed that some error exists between the mean value of a finite set of measurements and the true value, that is, averaging a number of measurements will only yield the true value if the number of measurements is infinite. If several subsets are taken from an infinite data population with a Gaussian distribution, then, by the central limit theorem, the means of the subsets will form a Gaussian distribution about the mean of the infinite data set. The standard deviation of mean values of a series of finite sets of measurements relative to the true mean (the mean of the infinite population that the finite set of measurements is drawn from) is defined as the standard error of the mean, α . This is calculated as

$$=\sigma/\sqrt{n}.$$
 (3.20)

Clearly, α tends toward zero as the number of measurements (n) in the data set expands toward infinity.

6

The next question is how do we use the standard error of the mean to predict the error between the calculated mean of a finite set of measurements and the mean of the infinite population? In other words, if we use the mean value of a finite set of measurements to predict the true value of the measured quantity, what is the likely error in this prediction? This likely error can only be expressed in probabilistic terms. All we know for certain is the standard deviation of the error, which is expressed as α in Equation (3.20). We also know that a range of \pm one standard deviation (i.e., $\pm \alpha$) encompasses 68% of the deviations of sample means either side of the true value. Thus we can say that the measurement value obtained by calculating the mean of a set of *n* measurements, x_1, x_2, \cdots, x_m , can be expressed as

x = xmmen ± a

with 68% certainty that the magnitude of the error does not exceed kd. For data set C of length measurements used earlier, n = 23, $\sigma = 1.88$, and $\alpha = 0.39$. The length can therefore be expressed as 406.5 \pm 0.4 (68% confidence limit).

The problem of expressing the error with 68% certainty is that there is a 32% chance that the error is greater than α . Such a high probability of the error being greater than α may not be acceptable in many situations. If this is the case, we can use the fact that ange of \pm two standard deviations, that is, $\pm 2\alpha$, encompasses 95.4% of the deviations of sample means either side of the true value. Thus, we can express the measurement value as

$$a = x_{mont} \pm 2\alpha$$

with 95.4% certainty that the magnitude of the error does not exceed l2al. This means that there is only a 4.6% chance that the error exceeds 2α . Referring again to set C of length measurements. $2\alpha = 3.76$, $2\alpha = 0.78$, and the length can be expressed as 406.5 \pm 0.8 (95.4% confidence limits).

If we wish to express the maximum error with even greater probability that the value is correct, we could use $\pm 3\alpha$ limits (99.7% confidence). In this case, for length measurements again, $3\sigma = 5.64$, $3\alpha = 1.17$, and the length should be expressed as 406.5 \pm 1.2 (99.7% confidence limits). There is now only a 0.3% chance (3 in 1000) that the error exceeds this value of 1.2.

3.6.7 Estimation of Random Error in a Single Measurement

In many situations where measurements are subject to random errors, it is not practical to take repeated measurements and find the average value. Also, the averaging process becomes invalid if the measured quantity does not remain at a constant value, as is usually the case when process variables are being measured. Thus, if only one measurement can be made, some means of estimating the likely magnitude of error in it is required. The normal approach to this is to calculate the error within 95% confidence limits, that is, to calculate the value of deviation D such that 95% of the area under the probability curve lies within limits of $\pm D$. These limits correspond to a deviation of $\pm 1.96\sigma$. Thus, it is necessary to maintain the measured quantity at a constant value while a number of measurements are taken in order to create a reference measurement set from which or can be calculated. Subsequently, the maximum likely deviation in a single **manus**trement can be expressed as Deviation = $\pm 1.96\sigma$. However, this only expresses the maximum likely deviation of the measurement from the calculated mean of the reference measurement set, which is not the true value as observed earlier. Thus the calculated value for the likely maximum deviation value. To he contistent, this should be expressed to the same 95% confidence limits. Thus, the maximum likely error in a single measurement can be expressed as

$$Error = \pm 1.96(\sigma + \alpha). \tag{3.21}$$

Before leaving this matter, it must be emphasized that the maximum error specified for a maximum error is any specified for the confidence limits defined. Thus, if the maximum error is

specified as $\pm 1\%$ with 95% confidence limits, this means that there is still 1 chance in 20 that the error will exceed $\pm 1\%$.

Example 3.7

Suppose that a standard mass is measured 30 times with the same instrument to create a reference data set, and the calculated values of σ and α are $\sigma = 0.46$ and $\alpha = 0.08$. If the instrument is then used to measure an unknown mass and the reading is 105.6 kg, how should the mass value be expressed?

Solution

Using Equation (3.21), 1.96($\sigma + \alpha$) = 1.06. The mass value should therefore be expressed as 105.6 ± 1.1 kg.

3.6.8 Distribution of Manufacturing Televances

Many aspects of manufacturing processes are subject to random variations caused by factors similar to those that cause random errors in measurements. In most cases, these random variations in manufacturing, which are known as *tolerances*, fit a Gaussian distribution, and the previous analysis of random measurement errors can be applied to analyze the distribution of these variations in manufacturing parameters.

Example 3.8

An integrated circuit chip contains 10⁵ transistors. The transistors have a mean current gain of 20 and a standard deviation of 2. Calculate the following:

(a) number of transistors with a current gain between 19.8 and 20.2

(b) number of transistors with a current gain greater than 17

Solution

(a) The proportion of transistors where 19.8 < gain < 20.2 is

P[X < 20] - P[X < 19.8] = P[z < 0.2] - P[z < -0.2] (for $z = (X - \mu)/\sigma$)

For X = 20.2, z = 0.1, and for X = 19.8, z = -0.1

From tables, P[z < 0.1] = 0.5398 and thus P[z < -0.1] = 1 - P[z < 0.1] = 1 - 0.5398 = 0.4602

Hence, P[z < 0.1] - P[z < -0.1] = 0.5398 - 0.4602 = 0.0796

19.8 to 20.2.

(b) The number of transistors with gain >17 is given by

$$P[x > 17] = 1 - P[x < 17] = 1 - P[z < -1.5] = P[z < +1.5] = 0.9332$$

Thus, 93.32%, that is, 93,320 transistors have a gain > 17.

3.6.9 Chi-Squared (X²) Distribution

We have already observed the fact that, if we calculate the mean value of successive sets of samples of N measurements, the means of those samples form a Gaussian distribution about the true value of the measured quantity (the true value being the mean of the infinite data set that the set of samples are part of). The standard deviation of the distribution of the mean values was quantified as the standard error of the mean.

It is also useful for many purposes to look at distribution of the variance of successive sets of samples of N measurements that form part of a Gaussian distribution. This is expressed as the chi-squared distribution $F(\chi^2)$, where χ^2 is given by

$$\chi^2 = k\sigma_x^2/\sigma^2, \qquad (3.22)$$

where σ_x is the variance of a sample of N measurements and σ^2 is the variance of the infinite data set that sets of N samples are part of k is a constant known as the number of degrees of freedom and is equal to (N - 1).

The shape of the χ^2 distribution depends on the value of k, with typical shapes being shown 10. The area under the χ^2 distribution curve is unity but, unlike the Gaussian distribution, the χ^2 distribution is not symmetrical. However, it tends toward the symmetrical shape of a Gaussian distribution as k becomes very large.

The z contribution expresses the expected variation due to random chance of the variance of a sample a wy from the variance of the infinite population that the sample is part of. The magnitude of this expected variation depends on what level of "random chance" we set. The level of random chance is normally expressed as a *level of significance*, which is usually



denoted by the symbol α . Referring to the χ^2 distribution shown in Figure 3.11, value χ^2 denotes the χ^2 value to the left of which lies $100(1-\alpha)$ % of the area under the χ^2 distribution curve. Thus, the area of the curve to the right of χ^2 is α and that to the left is $(1-\alpha)$.

Numerical values for χ^2 are obtained from tables that express the value of χ^2 for various degrees of freedom k and for various levels of significance α . Published tables differ in the number of degrees of freedom and the number of levels of significance covered. A typical table is shown as Table 3.2.

One major use of the χ^2 distribution is to predict the variance σ^2 of an infinite data set, given the measured variance σ_z^2 of a sample of N measurements drawn from the infinite population. The boundaries of the range of χ^2 values expected for a particular level of significance α can be expressed by the probability expression:

$$P[\chi^2_{1-\alpha/2} \le \chi^2 \le \chi^2_{\alpha/2}] = 1 - \alpha.$$
 (3.23)

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-	0.005	0.025	0.050	0.900	0.950	0.975	0.990	0.905	0,999
-	3 93r	.0'982	.0 393	2.71	3.84	5.02	6.63	7.88	10.8
	10-5								
2	0100	.0506	.103	4.61	5.99	7.38	9.21	10.6	13.8
-	0717	216	.352	6.25	7.81	9.35	11.3	12.8	16.3
3	0.207	484	.711	7.78	9 49	11.1	13.3	14.9	18.5
2	.412	.831	1.13	9.24	11.1	12.8	15.1	16.7	20.5
6	.676	1.24	1.64	10.6	12.6	14.4	16.8	18.5	22.5
7	989	1.69	2.17	12.0	14.1	16.0	18.5	20.3	24.3
É.	1.34	2.18	2.73	13.4	15.5	17.5	20.1	22.0	26.1
	1.73	2.70	3.33	14.7	16.9	19.0	21.7	23.6	27.9
10	2.16	3.25	3.94	16.0	18.3	20.5	23.2	25.2	29.6
11	2.60	3.82	4.57	17.3	19.7	21.9	24.7	26.8	31.3
12	3.07	4.40	5.23	18.5	21.0	23.3	26.2	28.3	32.9
13	3.57	5.01	5.89	19.8	22.4	24.7	27.7	29.8	34.5
14	4.07	5.63	6.57	21.1	23.7	26.1	29.1	31.3	36.1
15	4.60	6.26	7.26	22.3	25.0	27.5	30.6	32.8	37.7
16	5.14	6.91	7.96	23.5	26.3	28.8	32.0	34.3	39.3
17	5.70	7.56	8.67	24.0	27.6	30.2	33.4	35.7	40.8
18	6.26	8.23	9.39	26.0	28.9	31.8	34.8	37.2	42.3
19	6.84	8.91	10.1	27.2	30.1	32.9	36.2	38.6	43.8
20	7.43	9.59	10.9	28.4	31.4	34.2	37.6	40.0	45.3
21	8.03	10.3	11.6	29.6	32.7	35.5	38.9	41.4	46.8
22	8.64	11.0	12.3	30.8	33.9	36.8	40.3	42.8	48.3
23	9.26	11.7	13.1	32.0	35.2	38.1	41.6	44.2	49.7
24	9.89	12.4	13.8	33.2	36.4	39.4	43.0	45.6	\$1.2
25	10.5	13.1	14.6	34.4	37.7	40.6	44.3	46.9	52.6
26	11.2	13.8	15.4	35.6	38.9	41.0	45.6	48.3	541
27	11.8	14.6	16.2	36.7	40.1	43.2	47.0	49.6	55.5
28	12.5	15.3	16.9	37.9	41.3	44.5	48.3	\$1.0	56.9
29	13.1	16.0	17.7	39.1	42.6	45.7	49.6	\$2.3	58.3
30	13.8	16.8	18.5	40.3	43.8	47.0	50.9	\$1.7	59.7
35	17.2	20.6	12.5	46.1	49.8	53.2	57.3	60.3	55.6
40	20.7	24.4	26.5	51.8	55 R	50.5	63.7	66.8	73.4
45	24.3	28.4	30.6	\$7.5	61.7	65.4	70.0	73.2	80.1
50	26.0	32.4	34.8	63.2	67.5	71.4	76.2	78.5	86.7
75	47.2	52.9	56.1	91.1	96.2	100.8	106.4	110.3	118.6
00	67.3	74.2	77 0	118.5	124.3	120.6	136.0	148.2	1.40.4

Table 3.2 Chi-Squared (x²) Distribution

To part this is simpler terms, we are saying that there is a probability of $(1 - \alpha)$ % that χ^2 lies within the range bounded by $\chi^2_{1-\alpha} = \alpha \chi^2_{\alpha/2}$ for a level of significance of α . For example, for a level of significance $\alpha = 0.5$, there is a 95% probability (95% confidence level) that χ^2 lies between

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Substituting into Equation (3.23) using the expression for χ^2 given in Equation (3.22):

$$\mathbb{P}\left[\chi_{1-s/2}^2 \leq \frac{k\sigma_s^{-2}}{\sigma^2} \leq \chi_{s/2}^2\right] = 1-\alpha.$$

This can be expressed in an alternative but equivalent form by inverting the terms and changing the " \leq " relationships to " \geq " ones:

$$\mathbb{P}\left[\frac{1}{\chi^2_{1-\alpha/2}} \geq \frac{\sigma^2}{k\sigma_s^2} \geq \frac{1}{\chi^2_{\alpha/2}}\right] = 1 \to \alpha,$$

Now multiplying the expression through by $k\sigma_x^2$ gives the following expression for the boundaries of the variance σ^2 :

$$P\left[\frac{k\sigma_{k}^{2}}{|\vec{x}|_{-\eta/2}} \ge \sigma^{2} \ge \frac{k\sigma^{2}}{\vec{x}_{\eta/2}^{2}}\right] = 1 - \alpha.$$
 (3.24)

The thing that is immediately evident in this solution is that the range within which the true variance and standard deviation lies is very wide. This is a consequence of the relatively small number of measurements (10) in the sample. It is therefore highly desirable wherever possible to use a considerably larger sample when making predictions of the true variance and standard deviation of some measured quantity.

The solution to Example 3.10 shows that, as expected, the width of the estimated range is which the true value of the standard deviation lies gets wider as we increase the confidence level from 90 to 99%. It is also interesting to compare the results in Examples 3.9 and 3.10 for the same confidence level of 95%. The ratio between maximum and minimum values of estimated variance is much greater for the 10 samples in Example 3.9 compared with the 25 samples in Example 3.10. This shows the benefit of having a larger sample size when predicting the variance of the whole population that the sample is drawn from.

Example 3.9

The length of each rod in a sample of 10 brass rods is measured, and the variance of the length measurement in the sample is found to be 16.3 mm. Estimate the true variance and standard deviation for the whole batch of rods from which the sample of 10 was drawn, expressed to a confidence level of 95%.

Solution

Degrees of freedom (k) = N - 1 = 9For $\sigma_x^2 = 16.3$, $k\sigma_x^2 = 146.7$ For confidence level of 95%, level of significance, $\alpha_x = 0.05$ Applying Equation (3.24), the true variance is bounded by the values of 146.7/20 103 and 146.7/20 ces

Looking up the appropriate values in the χ^2 distribution table for k = 9 gives $\chi^2_{0.075} = 2.70$; $\chi^2_{0.025} = 19.02$; $146.7/\chi^2_{0.075} = 54.3$; $146.7/\chi^2_{0.025} = 7.7$ The true variance can therefore be expressed as $7.7 \le \sigma^2 \le 54.3$ The true standard deviation can be expressed as $\sqrt{7.7} \le \sigma \le \sqrt{54.3}$, that is, $2.8 \le \sigma \le 7.4$

III Example 3.10

The length of a sample of 25 bricks is measured and the variance of the sample is calculated as 6.8 mm. Estimate the true variance for the whole batch of bricks from which the sample of 25 was drawn, expressed to confidence levels of (a) 90%, (b) 95%, and (c) 99%.

Solution

Degrees of freedom (k) = N - 1 = 24For $\sigma_x^2 = 6.8$, $k\sigma_x^2 = 163.2$

(a) For confidence level of 90%, level of significance, $\alpha_s = 0.10$ and $\alpha/2 = 0.05$ Replying Equation (3.24), the true variance is bounded by the values of $163.2/\chi^2_{0.05}$ and $163.2/\chi^2_{0.05}$

Booking up the appropriate values in the χ^2 distribution table for k = 24 gives $\chi^2_{0.95} = 13.85$; $\chi^2_{0.05} = 36.42$; $163.2/\chi^2_{0.95} = 11.8$; $163.2/\chi^2_{0.05} = 4.5$ The true variance can therefore be expressed as $4.5 \le \sigma^2 \le 11.8$

(h) For confidence level of 95%, level of significance, $\alpha_{1} = 0.05$ and $\alpha/2 = 0.025$ Applying Equation (3.24), the true variance is bounded by the values of $163.2/\chi^{2}_{0.075}$ and $163.2/\chi^{2}_{0.015}$

Looking up the appropriate values in the χ^2 distribution table for k = 24 gives $\chi^2_{0.975} = 12.40$; $\chi^2_{0.025} = 39.36$; $163.2/\chi^2_{0.975} = 13.2$; $163.2/\chi^2_{0.023} = 4.1$ The true variance can therefore be expressed as $4.1 \le \sigma^2 \le 13.2$

(c) For confidence level of 99%, level of significance, $\alpha_1 = 0.01$ and $\alpha/2 = 0.005$ Applying Equation (3.24), the true variance is bounded by the values of 146.7/ $\chi^2_{0.005}$

Looking up the appropriate values in the χ^2 distribution table for k = 24 gives 9.89; $\chi_{0.005} = 45.56$; $163.2/\chi_0^2 = 16.5$; $163.2/\chi_{0.005} = 3.6$ The one variance can therefore be expressed as $3.6 \le \sigma^2 \le 16.5$

3.6.10 Goodness of Fit to a Gaussian Distribution

All of the analysis of random deviations presented so far only applies when data being analyzed belong to a Gaussian distribution. Hence, the degree to which a set of data fits a Gaussian distribution should always be tested before any analysis is carried out. This test can be carried out in one of three ways:

- (a) Inspecting the shape of the histogram: The simplest way to test for Gaussian distribution of data is to plot a histogram and look for a "bell shape" of the form shown earlier in Figure 3.6, Deciding whether the histogram confirms a Gaussian distribution is a matter of judgment. For a Gaussian distribution, there must always be approximate symmetry about the line through the center of the histogram, the highest point of the histogram must always coincide with this line of symmetry, and the histogram must get progressively smaller either side of this point. However, because the histogram can only be drawn with a finite set of measurements, some deviation from the perfect shape of histogram as described previously is to be expected even if data really are Gaussian.
- (b) Using a normal probability plot: A normal probability plot involves dividing data values into a number of ranges and plotting the cumulative probability of summed data frequencies against data values on special graph paper.⁹ This line should be a straight line if the data distribution is Gaussian. However, careful judgment is required, as only a finite number of data values can be used and therefore the line drawn will not be entirely straight even if the distribution is Gaussian. Considerable experience is needed to judge whether the line is straight enough to indicate a Gaussian distribution. This will be easier to understand if data in measurement set C are used as as example. Using the same five ranges as used to draw the histogram, the following table is first drawa:

Ranne	401.5 to 403.5	403.5 to 405.5	405.5 m	407.5 to 409.5	409.5 to 411.5
Number of data items in	1	5	11	5	1
range Cumulative number of data	1	6	17	22	23
Cumulative number of data	4.3	26.1	73.9	95 7	100.0

The normal probability plot drawn from this table is shown in Figure 3.12. This is sufficiently straight to indicate that data in measurement set C are Gaussian.

This is available from specialist stationery supplists.

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(c) The χ^2 test: The χ^2 distribution provides a more formal method for testing whether data follow a Gaussian distribution. The principle of the χ^2 test is to divide data into p equal width bins and to count the number of measurements n_1 in each bin, using exactly the name procedure as done to draw a histogram. The expected number of measurements n_1 in each bin for a Gaussian distribution is also calculated. Before proceeding any farther, a check must be raade at this stage to confirm that at least 80% of the bins have a data count greater than a minimum number for both n_1 and n_1 . We will apply a minimum number of four, although some statisticians use the smaller minimum of three and some use a larger minimum of five. If this check reveals that too many bins have data counts less than the minimum number, it is necessary to reduce the number of bins by redefining their width. The test for at least 10° of the bins exceeding the minimum number than has to be reapplied. Once the data count in the bins is satisfactory, a χ^2 value is calculated for data according to the following formula:

$$\chi^{2} = \sum_{i=1}^{p} \frac{(n_{i} - n_{i})^{2}}{n_{i}}$$
(3.25)

The χ test then examines whether the calculated value of χ^2 is greater than would expected for a Gaussian distribution according to some specified level of chance. This involves reading off the expected value from the χ^2 distribution table (Table 3.2) for the specified confidence level and comparing this expected value with that calculated (3.25). This procedure will become clearer if we work through an example.

Example 3.11

A sample of 100 pork pies produced in a bakery is taken, and the mass of each pie (grams) is measured. Apply the χ^2 test to examine whether the data set formed by the set of 100 mass measurements shown here conforms to a Gaussian distribution.

487 504 501 515 491 496 482 502 508 494 505 501 485 503 507 494 489 501 510 491 503 492 483 501 500 493 505 501 517 500 494 503 500 488 496 500 519 499 495 490 503 500 497 492 510 506 497 499 489 506 502 484 495 498 502 496 512 504 490 497 488 503 512 497 480 509 496 513 499 502 487 499 505 493 498 508 492 498 486 511 499 504 495 500 484 513 509 497 505 510 516 499 495 507 498 514 506 500 508 494

Solution

Applying the Sturgis rule, the recommended number of data bins p for N data points is given by

 $p = 1 + 3 3 \log_{10} N = 1 + (3.3)(2.0000) = 7.6.$

This rounds to 8.

Mass measurements span the range from 480 to 519. Hence we will choose data bin widths of 5 grams, with bin boundaries set at 479.5, 484.5, 489.5, 494.5, 499.5, 504.5, 509.5, 514.5 and 519.5 (boundaries set so that there is no ambiguity about which bin any particular data value fits in). The next step involves counting the number of measurements in each bin. These are the n, values, $i = 1, \dots 8$, for Equation (3.25). Results of this counting are set out in the following table.

Bin number (i)	1	2	3	4	5	6	7	
Data range	479,5	484.5	489.5	494.5	499 5	504.5	509.5	514.5
	to	80	60	00	10	00	60	00
	484.5	489.5	494.5	499.5	504.5	509.5	514.5	\$19.5
Measurements in range (n;)	5	8	13	23	24	14	9	4

Because none of the bins have a count less than our stated minimum threshold of four, we can now proceed to calculate n, values. These are the expected numbers of measurements in each data bin for a Gaussian distribution. The starting point for this calculation is knowing the mean value (μ) and standard deviation of the 100 mass measurements. These are calculated using Equations (3.4) and (3.10) as $\mu = 499.53$ and $\sigma = 8.389$. We now calculate the z values corresponding to the measurement values (x) at the upper end of each data bin using Equation (3.16) and then use the error function table (Table 3.1) to calculate *F*(z). *F*(z) gives the proportion of z values that are $\leq z$, which

gives the proportion of T measurements less than the corresponding z values. This then allows calculation of the z expected number of measurements $(n_z^{(1)})$ in each data bie. These calculations are shown in the following table.

ж	$z(\underline{\neg \underline{n-\mu}})$	F(z)	Expected number of data in bin (n,)
484 5	-1.792	0.837	3.7
489 5	-1.195	0.116	7.9
494.5	-0.0 600	0.274	15.8
499.5	-0. 0.004	0.498	22.4
504.5	0_0.592	0.723	22.5
509.5	1	0.883	16.0
514.5	1	0.963	8.0
519.5	2_1.381	0.991	2.8

In case there is any control fusion about the calculation of numbers in the final column, let us consider rows 1 and 222. Row 1 shows that the proportion of data points less than 484.5 is 0.037. Because there = are 100 data points in total, the actual estimated number of data points less than 488.84.5 is 3.7. Row 2 shows that the proportion of data points less than 489.5 is 0.11636, and hence the total estimated number of data points less than 489.5 is 11.6. This is total includes the 3.7 data points less than 484.5 calculated in the previous row. He sence, the number of data points in this bin between 484.5 and 489.5 is 11.6 minu as 3.7, that is, 7.9.

We can now calculate titche χ^2 value for data using Equation (3.25). The steps of the calculation are shown ins in the following table.

Bin number (p)	n	'n	$(n_i - n_i)$	$\left(n_{i}-n_{i}^{'}\right)^{2}$	<u>(a-a')</u>
	5	3.7	1.3	1.62	0.46
2	8	7.9	0.1	0.01	0.00
3	13	15.8	-2.8	7.84	0.50
4	23	22.4	0.6	0.36	0.02
3	24	22.5	1.5	2.25	0.10
4	14	16.0	-2.0	4.00	0.25
7	9	8.0	1.0	1.00	0.12
	4	2.8	1.2	1.44	0.51

The value of χ^2 is now four and by summing the values in the final column to give $\chi^2 = 1.96$. The final step is to chec and whether this value of χ^2 is greater than would be expected for a Gaussian distribution on. This involves looking up χ^2 in Table 3.2. Before doing this, we have to specify the num other of degrees of freedom, k. In this case, k is the number of bins minus 2, because domata are manipulated twice to obtain the μ and σ statistical values used in the calculation coof n_i^2 . Hence, k = 8 - 2 = 6.

Table 3.2 shows that, fector k = 6, $\chi^2 = 1.64$ for a 95% confidence level and $\chi^2 = 2.20$ for a 90% confidence level. Hence, our calculated value for χ^2 of 1.96 shows that the confidence level that dam.ta follow a Gaussian distribution is between 90% and 95%.

We will now look at a slightly different example where we meet the problem that our initial division of data into bins produces too many bins that do not contain the minimum number of data points necessary for the χ^2 test to work reliably.

Example 3.12

Suppose that the production machinery used to produce the pork pies featured in Example 3.11 is modified to try and reduce the amount of variation in mass. The mass of a new sample of 100 pork pies is then measured. Apply the χ^3 test to examine whether the data set formed by the set of 100 new mass measurements shown here conforms to a Gaussian distribution.

503 509 495 500 504 491 496 499 501 489 507 501 486 497 500 493 499 505 501 495 499 515 505 492 499 502 507 500 498 507 494 499 506 501 493 498 505 499 496 512 498 502 508 500 497 485 504 499 502 496 483 501 510 494 498 505 491 499 503 495 502 481 498 503 508 497 511 490 506 500 508 504 517 494 487 505 499 509 492 484 500 507 501 496 510 503 498 490 501 492 497 489 502 495 491 500 513 499 494 498

Solution

The recommended number of data bins for 100 measurements according to the Sturgis rule is eight, as calculated in Example 3.11. Mass measurements in this new data set span the range from 481 to 517. Hence, data bin widths of 5 grams are still suggested, with bin boundaries set at 479.5, 484.5, 489.5, 494.5, 499.5, 504.5, 509.5, 514.5, and 519.5. The number of measurements in each bin is then counted, with the counts given in the following table:

Bin number (i)	1	2	3	4	5	6	7	1.1
Data range	479.5	484.5	489.5	494.5	499.5	504.5	509.5	514.5
-	60	00	to	to	to	CD	to	60
	484.5	489.5	494.5	499.5	504.5	509.5	514.5	519.5
Measurements in range (R;)	3	5	14	29	26	16	5	2

Looking at these counts, we see that there are two bins with a count less than four. This amounts to 25% of the data bins. We have said previously that not more than 20% of data bins can have a data count less than the threshold of four if the χ^2 test is to operate reliably. Hence, we must combine the bins and count the measurements again. The usual approach is to combine pairs of bins, which in this case reduces the number of bins from eight to four. The boundaries of the new set of four bins are now 479.5, 489.5, 499.5, 509.5, and 519.5. New data ranges and counts are shown in the following table.

Bin number (i)	1	2	3	4
Data range	479.5 to 489.5	489 5 to 499 5	499.5 to 509.5	509.5 to 519.5
Measurements in		45	3.0	/

Now, none of the bins have a count less than our stated minimum threshold of four and so we can proceed to calculate n_i values as before. The mean value (μ) and standard deviation of the new mass measurements are $\mu = 499.39$ and $\sigma = 6.979$. We now calculate the z values corresponding to the measurement values (z) at the upper end of each data bin, read off the corresponding F(z) values from Table 3.1, and so calculate the expected number of measurements (n_i) in each data bin:

ж	z (<u>3-4</u>)	P(z)	Espected number of data in bin (rs)
489.5	-1.417	0.078	7.8
499 5	-0.016	0 494	41.6
509 5	1.449	0.926	43 2
519.5	2.882	0.996	7.2

We now calculate the χ^2 value for data using Equation (3.25). The steps of the calculation are shown in the following table.

Bin number (p)	ni		$(n_i - n_i)$	$(m - m)^2$	(n-n')"
1		7.8	0.2	0.04	0.005
2	43	41.6	1.4	1.96	0 047
3	42	43.2	-1.2	1.44	0.033
4	7	7.2	-0.2	0.04	0.006

The value of χ^2 is now found by summing the values in the final column to give $\chi^2 = 0.091$. The final step is to check whether this value of χ^2 is greater than would be expected for a Gaussian distribution. This involves looking up χ^2 in Table 3.2. This time, k = 2, as there are four bins and k is the number of bins minus 2 (as explained in the calculation of n,).

Table 3.2 shows that, for k = 2, $\chi^2 = 0.10$ for a 95% confidence level. Hence, our calculated value for χ^2 of 0.91 shows that the confidence level that data follow a Gaussian distribution is slightly better than 95%.

Out of interest, if the two bin counts less than four had been ignored and χ^2 had been calculated for the eight original data bins, a value of $\chi^2 = 2.97$ would have been domined. (It would be a useful exercise for the reader to check this for himself/herself.) For a difference of freedom (k = 8 - 2), the predicted value of χ^2 for a Gaussian population from Table 3.26.2.20 at a 90% confidence level. Thus the confidence that data fit a Gaussian distribution is substantially less than 90% given the χ^2 value of 2.97 calculated

for data. This result arises because of the unreliability associated with calculating χ^2 from data bin counts of less than four.

3.6.11 Rogue Date Points (Data Outliers)

In a set of measurements subject to random error, measurements with a very large error sometimes occur at random and unpredictable times, where the magnitude of the error is much larger than could reasonably be attributed to the expected random variations in measurement value. These are often called *rogue data points* or *data outliers*. Sources of such abnormal error include sudden transient voltage surges on the main power supply and incorrect recording of data (e.g., writing down 146.1 when the actual measurements, and a threshold level of a $\pm 3\sigma$ deviation is often used to determine what should be ducarded. It is rare for measurement errors to exceed $\pm 3\sigma$ limits when only aormal random effects are affecting the measured value.

While the aforementioned represents a reasonable theoretical approach to identifying and eliminating rogue data points, the practical implementation of such a procedure needs to be done with care. The main practical difficulty that exists in dealing with rogue data points is in establishing what the expected standard deviation of the measurements is. When a new set of measurements is being taken where the expected standard deviation is not known, the possibility exists that a rogue data point exists within the measurements. Simply applying a computer program to the measurements to calculate the standard deviation will produce an erroneous result because the calculated value will be biased by the rogue data point. The simplest way to overcome this difficulty is to plot a histogram of any new set of measurements and examine this manually to spot any data outliers. If no outliers are apparent, the standard deviation can be calculated and then used in a $\pm 3\sigma$ threshold against which to test all future measurements. However, if this initial data histogram shows up any outliers, these should be excluded from the calculation of the standard deviation.

It is interesting at this point to return to the problem of ensuring that there are no outliers in the set of data used to calculate the standard deviation of data and hence the threshold for rejecting outliers. We have suggested that a histogram of some initial measurements be drawn and examined for outliers. What would happen if the set of data given earlier in Example 3.13 was the initial data set that was examined for outliers by drawing a histogram? What would happen if we did not spot the outlier of 4.99? This question can be answered by looking at the effect on the calculated value of standard deviation if this rogue data point of 4.59 is lacluded in the calculation. The standard deviation calculated over the 19 values, excluding the 4.59

memory. is 0.052. The standard deviation calculated over the 20 values, including the 4.59 including the 0.053 and the mean data value is changed to 0.42. This gives a 3 σ threshold of 0.19, and the boundaries for the \pm 3 σ threshold operation are now 4.23 and 4.61. This does not enclude the data value of 4.59, which we identified previously as a being a rogue data point! This confirms the necessity of looking carefully at the initial set of data used to calculate the thresholds for rejection of the rogue data point to ensure that initial data do not contain any rogue data points. If drawing and examining a histogram do not clearly show that there are no rogue data points in the "reference" set of data, it is worth taking another set of measurements to see whether a generate set of data can be obtained that is more clearly free of rogue data points.

Example 3.13

A set of measurements is made with a new pressure transducer. Inspection of a histogram of the first 20 measurements does not show any data outliers. The standard deviation of the measurements is calculated as 0.05 bar after this check for data outliers, and the mean value is calculated as 4.41. Following this, the following further set of measurements is obtained:

4.35 4.46 4.39 4.34 4 41 4.52 4.44 4.37 4.41 4.33 4.39 4.47 4 42 4.59 4 45 4 38 4.43 4.36 4 48 4.45

Use the $\pm 3\sigma$ threshold to determine whether there are any rogue data points in the measurement set.

Solution

Because the calculated σ value for a set of "good" measurements is given as 0.05, the \pm 3 σ threshold is \pm 0.15. With a mean data value of 4.41, the threshold for rogue data points is values below 4.26 (mean value minus 3 σ) or above 4.56 (mean value plue 3 σ). Booking at the set of measurements, we observe that the measurement of 4.59 is outside the \pm 3 σ threshold, indicating that this is a rogue data point.

3.6.12 Student & Distribution

when the number of measurements of a quantity is particularly small (less than about 30 simples) and statistical analysis of the distribution of error values is required, the possible intrinse of the meas of measurements from the true measurement value (the meas of the intrinse population that the sample is part of) may be significantly greater than is suggested by analy is based on a z distribution. In response to this, a statistician called William Gonset diveloped an alternative distribution function that gives a more accurate prediction of the error

distribution when the number of samples is small. He published this under the pseudonym "Student" and the distribution is commonly called *student t distribution*. It should be noted that t distribution has the same requirement as the z distribution in terms of the necessary for data to belong to a Gaussian distribution.

The student t variable expresses the difference between the mean of a small sample (x_{mean}) and the population mean (μ) in terms of the following ratio:

$$l = \frac{|\text{error in mean}|}{\text{standard error of the mean}} = \frac{|\mu - \pi_{\text{mean}}|}{\sigma/\sqrt{N}},$$
 (3.26)

Because we do not know the exact value of σ , we have to use the best approximation to σ that we have, which is the standard deviation of the sample, σ_x . Substituting this value for σ in Equation (3.26) gives

$$t = \frac{|\mu - x_{max}|}{\sigma_s / \sqrt{N}}.$$
 (3.27)

Note that the modulus operation $(1 \cdots 1)$ on the error in the mean in Equations (3.26) and (3.27) means that t is always positive.

The shape of the probability distribution curve F(t) of the t variable varies according to the value of the number of degrees of freedom, k (= N - 1), with typical curves being shown in Figure 3.13, An $k \rightarrow \infty$, $F(t) \rightarrow F(z)$, that is, the distribution becomes a standard Gaussian one. For values of $k < \infty$, the curve of F(t) against t is both narrower and less high in the center than a standard Gaussian curve, but has the same properties of symmetry about t = 0 and a total area under the curve of unity.

In a similar way to z distribution, the probability that t will lie between two values t_1 and t_2 is given by the area under the F(t) curve between t_1 and t_2 . The t distribution is published in the form of a standard table (see Table 3.3) that gives values of the area under the curve α for various values of k, where

$$\alpha = \int_{t_1}^{\infty} F(t) dt. \qquad (3.28)$$

The area α is shown in Figure 3.14, α corresponds to the probability that *t* will have a value greater than t_3 to some specified confidence level. Because the total area under the *F(t)* curve is unity, there is also a probability of $(1 - \alpha)$ that *t* will have a value less than t_3 . Thus, for a value $\alpha = 0.05$, there is a 95% probability (i.e., a 95% confidence level) that $t < t_3$.



Figure 3.13 Typical t-distribution curves.

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Table 5.3 F	Chief Printer Planet
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	a = 0.10	m = 0.05	# = 0.025	m = 0.01	a = 0.005	a = 9.001
1	3.076	6.314	12.71	31.82	63.66	518.3
2	1.846	2.920	4.303	6.965	9.925	23.55
3	1.638	2.353	3.182	4.541	5.841	10.21
4	1.533	2.132	2.776	3.747	4.604	7.173
5	1.476	2.015	2.571	3.365	4.032	5.893
6	1,640	1.943	2.447	3.143	3.707	5.208
7	1.415	1.895	2.365	2,998	3.499	4.785
4	1.397	1.860	2.306	2.896	3.355	4.501
	1.583	1.833	2.262	2.821	3.250	4.297
10	1.372	1.812	2.228	2,764	3,169	4,144
11	1.363	1.796	2.201	2,718	3,106	4.025
12	1.356	1.782	2.179	2.681	3.055	3,990
13	1.350	1.771	2,160	2.640	3.012	3.852
14	1.345	1.761	2.145	2.624	2.977	3.787
15	1.341	1.753	2.131	2,602	2.947	3.733
16	1.337	1.746	2.120	2.583	2.921	3.686
17	1.333	1,740	2.110	2.567	2.898	3.646
18	1.330	1.734	2.101	2.552	2.878	3.610
19	1.378	1.729	2.093	2.539	2.861	3.579
20	1.325	1.725	2.086	2.528	2.845	3.552
21	1.323	1.721	2.080	2.518	2.831	3.527
22	1.321	1.717	2.074	2 508	2.819	3.505
23	1.319	1.714	2.069	2.500	2.807	3.485
24	1.318	1,711	2.064	2.492	2 797	3.467
25	1.316	1,708	2.060	2.485	2,787	3,450
26	1.315	1,706	2.056	2.479	2.779	3.435
27	1.314	1,703	2.052	2.473	2.771	3.471
28	1.313	1,701	2.048	2.467	2.763	3.408
29	1.311	1,699	2.045	2.467	2,756	3.396
30	1.310	1.697	2.047	2.457	2,750	3.385

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Meaning of area t for t-distribution curve.

Because of the symmetry of t distribution, a is also given by

$$\mathbf{z} = \int_{-\infty}^{-\mathbf{t}_1} \mathbf{F}(\mathbf{t}) d\mathbf{t}$$
 (3.29)

as shown in Figure 3.15. Here, α corresponds to the probability that *t* will have a value less than $-t_3$, with a probability of $(1 - \alpha)$ that *t* will have a value greater than $-t_3$.

Equations (3.28) and (3.29) can be combined to express the probability $(1 - \alpha)$ that *t* lies between two values $-t_4$ and $+t_4$. In this case, α is the sum of two areas of $\alpha/2$ as shown in Figure 3.16. These two areas can be represented mathematically as

$$\frac{\alpha}{2} = \int_{-\infty}^{-\alpha} F(t) dt \text{ (left-hand area) and } \frac{\alpha}{2} = \int_{t_0}^{\infty} F(t) dt \text{ (right-hand area).}$$



Alternative interpretation of area ti for t-distribution curve.



Area between $-\alpha/2$ and $+\alpha/2$ on t-distribution curve,

The values of t₄ can be found in any *t* distribution table, such as Table 3.3, Referring back to Equation (3.27), this can be expressed in the form:

$$|\mu - 3_{mm} = \frac{1\sigma_s}{\sqrt{N}}|.$$

Hence, upper and lower bounds on the expected value of the population mean μ (the true value of x) can be expressed as

$$-\frac{l_4\sigma_x}{\sqrt{N}} \le \mu - x_{max} \le +\frac{l_4\sigma_x}{\sqrt{N}}$$

$$x_{max} - \frac{l_4\sigma_x}{\sqrt{N}} \le \mu \le x_{max} + \frac{l_4\sigma_x}{\sqrt{N}}$$
(3.30)

Out of interest, let us examine what would have happened if we had calculated the error bounds μ using standard Gaussian (z-distribution) tables. For 95% confidence, the maximum error is given as $\pm 1.96\sigma/\sqrt{N}$, that is, ± 0.96 , which rounds to ± 1.0 mm, meaning the mean meaning diameter is given as 105.4 ± 1.0 mm. The effect of using *t* distribution instead of the clearly expands the magnitude of the likely error in the mean value to components.

Example 3.14

The riternal diameter of a sample of hollow castings is measured by destructive testing of 1.5 the taken randomly from a large batch of castings. If the sample mean is 105.4 mm with a idard deviation of 1.9 mm, express the upper and lower bounds to a confidence level of 95% on the range in which the mean value lies for internal diameter of the whole batch.

8

Solution

For 15 samples (N = 15), the number of degrees of freedom (k) = 14.

For a confidence level of 95%, $\alpha = 1 - 0.95 = 0.05$. Looking up the value of t in Table 3.3 for k = 14 and $\alpha/2 = 0.025$ gives t = 2.145. Thus, applying Equation (3.30):

$$105.4 - \frac{(2.145)(1.9)}{\sqrt{15}} \le \mu \le 105.4 + \frac{(2.145)(1.9)}{\sqrt{15}}$$

that is, $104.3 \le \mu \le 106.5$.

Thus, we would express the mean internal diameter of the whole batch of castings as 105.4 \pm 1.1 mm.

3.7 Aggregation of Measurement System Errors

Errors in measurement systems often arise from two or more different sources, and these must be aggregated in the correct way in order to obtain a prediction of the total likely error in output readings from the measurement system. Two different forms of aggregation are required: (1) a single measurement component may have both systematic and random errors and (2) a measurement system may consist of several measurement components that each have separate errors.

3.7.1 Combined Effect of Systematic and Random Errors

If a measurement is affected by both systematic and random errors that are quantified as $\pm x$ (systematic errors) and $\pm y$ (random errors), some means of expressing the combined effect of both types of errors is needed. One way of expressing the combined error would be to sum the two separate components of error, that is, to say that the total possible error is $e = \pm (x + y)$. However, a more usual course of action is to express the likely maximum error as

$$r = \sqrt{(x^2 + y^2)}.$$
 (3.31)

It can be shown (ANSI/ASME, 1985) that this is the best expression for the error statistically, as it takes into account the reasonable assumption that the systematic and random errors are independent and so it is unlikely that both will be at their maximum or minimum value simultaneously.

3.7.2 Aggregation of Errors from Separate Measurement System Compensata

A measurement system often consists of noveral separate components, each of which is subject in errors. Therefore, what remains to be investigated is how errors associated with each measurement system component combine together so that a total error calculation can be meas for the complete measurement system. All four mathematical operations of addition, autoration, multiplication, and division may be performed on measurements derived from different instruments/transducers in a measurement system. Appropriate techniques for the vertices situations that arise are covered later.

Error in a sum

If the two outputs y and z of separate measurement system components are to be added together, we can write the sum as S = y + z. If the maximum errors in y and z are $\pm ay$ and $\pm bz$, respectively, we can express the maximum and minimum possible values of S as

$$S_{max} = (y + ay) + (z + bz); S_{max} = (y - ay) + (z - bz); \text{ or } S = y + z \pm (ay + bz).$$

This relationship for S is not convenient because in this form the error term cannot be expressed as a fraction or percentage of the calculated value for S. Fortunately, statistical analysis can be applied (see Topping, 1962) that expresses S in an alternative form such that the most probable maximum error $\ln S$ is represented by a quantity e, where e is calculated in terms of the *mbsolute* errors as

$$e = \sqrt{(ay)^2 + (bz)^2}$$
, (3.32)

Thus $S = (y + z) \pm e$. This can be expressed in the alternative form:

$$S = (y + z)(1 \pm f),$$
 (3.33)

where f = e/(y + z).

It should be noted that Equations (3.32) and (3.33) are only valid provided that the measurements are uncorrelated (i.e., each measurement is entirely independent of the others).

Example 3.15

A circuit requirement for a resistance of 550 Ω is satisfied by connecting together two resistance of nominal values 220 and 330 Ω in series. If each resistor has a tolerance of a roor in the sum calculated according to Equations (3.32) and (3.33) is given by

$$e = \sqrt{(0.02 \times 220)^2 + (0.02 \times 330)^2} = 7.93$$
; $f = 7.93/50 = 0.0144$

Thus the total resistance S can be expressed as $S = 550 \ \Omega \pm 7.93 \ \Omega$ or $S = 550 \ (1 \pm 0.0144) \ \Omega$, that is, $S = 550 \ \Omega \pm 1.4\%$

Error in a difference

If the two outputs y and z of separate measurement systems are to be subtracted from one another, and the possible errors are \pm sy and \pm bz, then the difference S can be expressed (using statistical analysis as for calculating the error in a sum and assuming that the measurements are uncorrelated) as

$$S = (y - z) \pm e$$
 or $S = (y - z)(1 \pm f)$.

where e is calculated as in Equation (3.32) and f = e/(y - z).

This example illustrates very poignantly the relatively large error that can arise when calculations are made based on the difference between two measurements.

Example 3.16

A fluid flow rate is calculated from the difference in pressure measured on both sides of an orifice plate. If the pressure measurements are 10.0 and 9.5 bar and the error in the pressure measuring instruments is specified as \pm 0.1%, then values for *s* and *f* can be calculated as

$$=\sqrt{(0.001\times10)^2+(0.001\times9.5)^2}=0.0138 \ ; \ f=0.0138/0.5=0.0276$$

Error in a product

If outputs y and z of two measurement system components are multiplied together, the product can be written as P = yz. If the possible error in y is $\pm ay$ and in z is $\pm bz$, then the maximum and minimum values possible in P can be written as

$$P_{\max} = (y + ay)(z + bz) = yz + ayz + byz + aybz ; P_{\min} = (y - ay)(z - bz) = yz - ayz - byz + aybz.$$

For typical measurement system components with output errors of up to 1 or 2% in magnitude. both a and b are very much less than one in magnitude and thus terms in aybz are begligible compared with other terms. Therefore, we have $P_{max} = yz(1 + a + b)$; $P_{max} = yz(1 - a - b)$. Thus the maximum error in product P is $\pm (a + b)$. While this expresses the maximum gossible error in P, it tends to overestimate the likely maximum error, as it is very unlikely that the errors in y and z will both be at the maximum or minimum value at the same time. A statistically better estimate of the likely maximum error e in product P, provided that the measurements are uncorrelated, is given by Topping (1962);

$$e = \sqrt{a^2 + b^2}$$
. (3.34)

Note that in the case of multiplicative errors, e is calculated in terms of fractional errors in v and a (as opposed to absolute error values used in calculating additive errors).

Example 3.17

If the power in a circuit is calculated from measurements of voltage and current in which the calculated maximum errors are, respectively, ± 1 and $\pm 2\%$, then the maximum error in the calculated power value, calculated using Equation (3.34) is $\pm 0.01^2 \pm 0.02^2 = \pm 0.022$ or $\pm 2.2\%$.

Error in a quotient

If the output measurement y of one system component with possible error $\pm sy$ is divided by the output measurement z of another system component with possible error $\pm bz$, then the maximum and minimum possible values for the quotient can be written as

$$Q_{\max} = \frac{y + ay}{z - bz} = \frac{(y + ay)(z + bz)}{(z - bz)(z + bz)} = \frac{yz + ayz + byz + aybz}{z^2 - b^2 z^2};$$
$$Q_{\max} = \frac{y - ay}{z + bz} = \frac{(y - ay)(z - bz)}{(z + bz)(z - bz)} = \frac{yz - ayz - byz + aybz}{z^2 - b^2 z^2}.$$

For a < 1 and b << 1, terms in ab and b^2 are negligible compared with the other terms. Hence $Q_{\max} = \frac{yz(1+a+b)}{z^2}$; $Q_{\max} = \frac{yz(1-a-b)}{z^2}$; that is, $Q = \frac{y}{z} \pm \frac{y}{z}(a+b)$. Thus the maximum error in the quotient is $\pm (a+b)$. However, using the same argument is made particular for the product of measurements of the same argument.

is made satisfy for the product of measurements, a statistically better estimate (see Topping, 1952) of the likely maximum error in the quotient Q, provided that the measurements are uncorrelated, is that given in Equation (3.34),

Example 3.18

If the density of a substance is calculated from measurements of its mass and volume the respective errors are ± 2 and $\pm 3\%$, then the maximum likely error in the density relation (3.34) is $\pm \sqrt{0.02^2 + 0.003^2} = \pm 0.036$ or $\pm 3.6\%$.

3.7.3 Total Error When Combining Multiple Measurements

The final case to be covered is where the final measurement is calculated from aeveral measurements that are combined together in a way that involves more than one type of arithmetic operation. For example, the density of a rectangular-aided solid block of material can be calculated from measurements of its mass divided by the product of measurements of its length, height, and width. Because errors involved in each stage of arithmetic are cumulative, the total measurement error can be calculated by adding together the two error values associated with the two multiplication stages involved in calculating the volume and then calculating the error in the final arithmetic operation when the mass is divided by the volume.

Example 3.19

A rectangular-sided block has edges of lengths a, b, and c, and its mass is m. If the values and possible errors in quantities a, b, c, and m are as shown, calculate the value of density and the possible error in this value.

 $a = 100 \text{ mm} \pm 1\%$, $b = 200 \text{ mm} \pm 1\%$, $c = 300 \text{ mm} \pm 1\%$, $m = 20 \text{ kg} \pm 0.5\%$.

Solution

Value of $ab = 0.02 \text{ m}^2 \pm 2\%$ [possible error = 1% + 1% = 2%] Value of (ab)c = 0.006 m³ ± 3% [possible error = 2% + 1% = 3%] Value of $\frac{m}{abc} = \frac{20}{0.006} = 3330 \text{ kg/m}^3 \pm 3.5\%$ [possible error = 3% + 0.5% = 3.5%]

3.8 Summary

This chapter introduced the subject of recesurement uncertainty, and the length of the chapter gives testimony to the great importance attached to this subject. Measurement errors are a fact of life and, although we can do much to reduce the magnitude of errors, we can never reduce errors entirely to zero. We started the chapter off by noting that measurement uncertainty comes in two distinct forms, known respectively as systematic error and random error. We learned that the nature of systematic errors was such that the effect on a measurement reading was to make it either consistently greater than or consistently less than the true value of the measurements of a constant quantity are randomly both greater than and less than the true value of the measurements of a constant.

In our subsequent study of systematic measurement errors, we first examined all the sources of this kind of error. Following this, we looked at all the techniques available for reducing the magnitude of systematic errors arising from the various error sources identified. Finally, we examined ways of quantifying the remaining systemic measurement error after all reasonable means of reducing error magnitude had been applied.

Our study of random measurement errors also started off by studying ty pical sources of these. We observed that the nature of random errors means that we can get close to the correct value of the measured quantity by averaging over a number of measurements, although we noted that en could never actually get to the correct value unless we achieved the impossible task of having an infinite number of measurements to average over. We found that how close we get to the correct value depends on how many measurements we average over and how widely the measurements are spread. We then examined the two alternative ways of calculating average in terms of the mean and median value of a set of measuremenas. Following this, we looked at ways of expressing the spread of measurements about the measu/median value. This led to the formal mathematical quantification of spread in terms of standard deviation and variance. We then started to look at graphical ways of expressing the appread. Initially, we considered representations of spread as a histogram and then went on to show how histograms expand into frequency distributions in the form of a smooth curve. We found that truly random data are described by a particular form of frequency distribution knowrs as Gaussian (or mermal). We introduced the z variable and saw how this can be used to emaimate the number of measurements in a set of measurements that have an error magnitude between two specified values. Following this, we looked at the implications of the fact that we can only over have a finite number of measurements. We saw that a variable called the standard error of the mean could be calculated that estimates the difference between the mean value of a finite set of measurements and the true value of the measured quantity (the mean of an infinite data ent). We went on to look at how this was useful in estimating the likely error in a single measurement subject to random errors in the situation where it is not possible to average over a number of measurements. As an aside, we then went on to look at how the z variable was useful in analyzing tolerances of manufactured components subject to random variations in a parallel way to the analysis of measurements subject to random wariations. Following this, we went on to look at y distribution. This can be used to quantify the variation in the variance of a finite set of measurements with respect to the variance of the infinite set that the finite set is part of. Up until this point in the chapter, all analysis of random errors assumed that the measurement set fitted a Gaussian distribution. However, this assumption must always be justified by applying goodness of fit tests, so these were explained in the following section, where we are that a χ^2 test is the most rigorous test available for goodness of fit. A particular problem that can affect the analysis of random errors adveragely is the presence of rogue data points (data outliers) in measurement data. These were considered, and the conditions under which they can justifiably be excluded from the analyzed data set were explored. Finally, we saw that yet another problem that can affect the analysis of random errors is where the measurement set only has a small number of values. In this case,

calculations based on z distribution are inaccurate, and we explored the use of a better distribution called *s* distribution.

The chapter ended with looking at how the effects of different measurement errors are aggregated together to predict the total error in a measurement system. This process was considered in two parts. First, we looked at how systematic and random error magnitudes can be combined together in an optimal way that best predicts the likely total error in a particular measurement. Second, we looked at situations where two or more measurements of different quantities are combined together to give a composite measurement value and looked at the best way of dealing with each of the four arithmetic operations that can be carried out on different measurement components.

3.9 Problems

- 3.1. Explain the difference between systematic and random errors. What are the typical sources of these two types of errors?
- 3.2. In what ways can the act of measurement cause a disturbance in the system being measured?
- 3.3. In the circuit shown in Figure 3.17, the resistor values are given by $R_1 = 1000 \Omega$; $R_2 = 1000 \Omega$; V = 20 volts. The voltage across AB (i.e., across R_2) is measured by a voltmeter whose internal resistance is given by $R_m = 9500 \Omega$.
 - (a) What will be the reading on the voltmeter?
 - (b) What would the voltage across AB be if the voltmeter was not loading the circuit (i.e., if R_m = infinity)?
 - (c) What is the measurement error due to the loading effect of the voltmeter?
- 3.4. Suppose that the components in the circuit shown in Figure 3.1a have the following values:

$R_1 = 330 \Omega; R_2 = 1000 \Omega; R_3 = 1200 \Omega; R_4 = 220 \Omega; R_5 = 270 \Omega.$

If the instrument measuring the output voltage across AB has a resistance of 5000 Ω , what is the measurement error caused by the loading effect of this instrument?



- 3.5. (a) Explain what is meant by the term "modifying inputs."
 - (b) Explain briefly what measures can be taken to reduce or eliminate the effect of modifying inputs.
- 3.6. Instruments are normally calibrated and their characteristics defined for particular standard ambient conditions. What procedures are normally taken to avoid measurement errors when using instruments subjected to changing ambient conditions?
- 3.7. The voltage across a resistance R₃ in the circuit of Figure 3.18 is to be measured by a voltmeter connected across it.
 - (a) If the voltmeter has an internal resistance (R_m) of 4750 Ω , what is the measurement error?
 - (b) What value would the volumeter internal resistance need to be in order to reduce the measurement error to 1%?
- 3.8. In the circuit shown in Figure 3.19, the current flowing between A and B is measured by an ammeter whose internal resistance is 100Ω . What is the measurement error caused by the resistance of the measuring instrument?



Figure 3.18 Circuit for Problem 3.7.



- 3.9. What steps can be taken to reduce the effect of onvironmental inputs in measurement systems?
- 3.10. (a) Explain why a voltmeter never reads exactly the correct value when it is applied to an electrical circuit to measure the voltage between two points.
 - (b) For the circuit shown in Figure 3.17, show that the voltage E_m measured across points AB by the voltmeter is related to the true voltage E_m by the following expression:

$$\frac{E_m}{E_n} = \frac{R_m(R_1 + R_2)}{R_1(R_2 + R_m) + R_2R_m}$$

- (c) If the parameters in Figure 3.17 have the following values, $R_1 = 500 \Omega$; $R_2 = 500 \Omega$; $R_m = 4750 \Omega$, calculate the percentage error in the voltage value measured across points AB by the volumeter.
- 3.11. The output of a potentiometer is measured by a voltmeter having resistance R_m , as shown in Figure 3.20, R_i is the resistance of the total length X_i of the potentiometer, and R_i is the resistance between the wiper and common point C for a general wiper position X_i . Show that the measurement error due to the resistance, R_m , of the measuring instrument is given by

Error =
$$E \frac{R_i^2(R_i - R_i)}{R_i(R_iR_i + R_mR_i - R_i^2)}$$
.

Hence show that the maximum error occurs when X_i is approximately equal to $2X_i/3$. (Hint: differentiate the error expression with respect to R_i and set to 0. Note that maximum error does not occur exactly at $X_i = 2X_i/3$, but this value is very close to the position where the maximum error occurs.)

3.12. In a survey of 15 owners of a certain model of car, the following values for average fuel consumption were reported:

25.5 30.3 31.1 29.6 32.4 39.4 28.9 30.0 33.3 31.4 29.5 30.5 31.7 33.0 29.2

Calculate mean value, median value, and standard deviation of the data set.



Figure 3.20 Circuit for Problem 3.11.

3.13 The following 10 measurements of the freezing point of aluminum were made using a platinum/rhodium thermocouple:

658.2 659.8 661.7 662.1 659.3 660.5 657.9 662.4 659.6 662.2

Find (a) median, (b) mean, (c) standard deviation, and (d) variance of the measurements. 3.14. The following 25 measurements were taken of the thickness of steel emerging from a rolling mill:

3.97 3.99 4.04 4.00 3.98 4 03 4.00 3.98 3.99 3.96 4.02 3.99 4.01

3.97 4.02 3.99 3.95 4.03 4.01 4.05 3.98 4.00 4.04 3.98 4.02

Find (a) median, (b) mean, (c) standard deviation, and (d) variance of the measurements. 3.15. The following 10 measurements were made of output voltage from a high-gain

amplifier contaminated due to noise fluctuations:

1.53, 1.57, 1.54, 1.54, 1.50, 1.51, 1.55, 1.54, 1.56, 1.53

Determine the mean value and standard deviation. Hence, estimate the accuracy to which the mean value is determined from these 10 measurements. If 1000 measurements were taken, instead of 10, but σ remained the same, by how much would the accuracy of the calculated mean value be improved?

3.16. The following measurements were taken with an analogue meter of current flowing in a circuit (the circuit was in steady state and therefore, although measurements varied due to random errors, the current flowing was actually constant):

21.5, 22.1, 21.3, 21.7, 22.0, 22.2, 21.8, 21.4, 21.9, 22.1 mA

Calculate mean value, deviations from the mean, and standard deviation.

- Using the measurement data given in Problem 3.14, draw a histogram of errors (use error bands 0.03 units wide, i.e., the center band will be from -0.015 to +0.015).
- 3.18. (a) What do you understand by the term probability density function?
 - (b) Write down an expression for a Gaussian probability density function of given mean value μ and standard deviation σ and show how you would obtain the best estimates of these two quantities from a sample of population n.
- Measurements in a data set are subject to random errors, but it is known that the data set fits a Gaussian distribution. Use standard Gaussian tables to determine the percentage of measurements that lie within the boundaries of $\pm 1.5\sigma$, where σ is the standard deviation of the measurements.
- 3.20. Measurements in a data set are subject to random errors, but it is known that the data set fine a Gaussian distribution. Use error function tables to determine the value of x bequired such that 95% of the measurements lie within the boundaries of $\pm x\sigma$, where σ is standard deviation of the measurements.

3.21.	By applying error function tables for mean and standard deviation values calculated in
	Problem 3.14, estimate

(a) How many measurements are <4.00?

(b) How many measurements are < 3.95?

(c) How many measurements are between 3.98 and 4.02?

Check your answers against real data.

3.22. The resolution of the instrument referred to in Problem 3.14 is clearly 0.01. Because of the way in which error tables are presented, estimations of the number of measurements in a particular error band are likely to be closer to the real number if boundaries of the error band are chosen to be between measurement values. In part c of Problem 3.21, values > 3.98 are subtracted from values > 4.02, thus

excluding measurements equal to 3.98. Test this hypothesis out by estimating:

- (a) How many measurements are <3.995?
- (b) How many measurements are < 3.955?
- (c) How many measurements are between 3.975 and 4.025? Check your answers against real data.
- 3.23. Measurements in a data set are subject to random errors, but it is known that the data set fits a Gaussian distribution. Use error function tables to determine the percentage of measurements that lie within the boundaries of $\pm 2\sigma$, where σ is the standard deviation of the measurements.
- 3.24. A silicon-integrated circuit chip contains 5000 ostensibly identical transistors. Measurements are made of the current gain of each transistor. Measurements have a mean of 20.0 and a standard deviation of 1.5. The probability distribution of the measurements is Gaussian.
 - (a) Write down an expression for the number of transistors on the chip that have a current gain between 19.5 and 20.5.
 - (b) Show that this number of transistors with a current gain between 19.5 and 20.5 is approximately 1300.
 - (c) Calculate the number of transistors that have a current gain of 17 or more (this is the minimum current gain necessary for a transistor to be able to drive the succeeding stage of the circuit in which the chip is used).

3.25. In a particular manufacturing process, bricks are produced in batches of 10,000. Because of random variations in the manufacturing process, random errors occur in the target length of the bricks produced. If the bricks have a mean length of 200 mm with a standard deviation of 20 mm, show how the error function tables supplied can be used to calculate the following:

(a) number of bricks with a length between 198 and 202 mm.

(b) number of bricks with a length greater than 170 mm.

3.26. The temperature-controlled environment in a hospital intensive care unit is monitored by an intelligent instrument that measures temperature every minute and calculates the mean and standard deviation of the measurements. If the mean is $75^{\circ}C$ and the standard deviation is 2.15,

(a) What percentage of the time is the temperature less than 70°C?

(b) What percentage of the time is the temperature between 73 and 77°C?

- 2.27. Calculate the standard error of the mean for measurements given in Problem 3.13.
- Hence, express the melting point of aluminum together with the possible error in the value expressed.
- 3.28. The thickness of a set of gaskets varies because of random manufacturing disturbances, but thickness values measured belong to a Gaussian distribution. If the mean thickness is 3 mm and the standard deviation is 0.25, calculate the percentage of gaskets that have a thickness greater than 2.5 mm.
- 3.29. If the measured variance of 25 samples of bread cakes taken from a large batch is 4.85 grams, calculate the true variance of the mass for a whole batch of bread cakes to a 95% significance level.
- 3.30. Calculate true standard deviation of the diameter of a large batch of tires to a confidence level of 99% if the measured standard deviation in the diameter for a sample of 30 tires is 0.63 cm.
- 3.31. One hundred fifty measurements are taken of the thickness of a coil of rolled steel sheet measured at approximately equidistant points along the center line of its length. Measurements have a mean value of 11.291 mm and a standard deviation of 0.263 mm. The smallest and largest measurements in the sample are 10.73 and 11.89 mm. Measurements are divided into eight data bins with boundaries at 10.695, 10.845, 10.995, 11.145, 11.295, 11.445, 11.595, 11.745, and 11.895. The first bin, containing measurements between 10,695 and 10.845, has eight measurements in it, and the count of measurements in the following successive bins is 12, 21, 34, 31, 25, 14, and 5. Apply the χ^2 test to see whether the measurements fit a Gaussian distribution to a 95% confidence level.
- 3.32. The temperature in a furnace is regulated by a control system that aims to keep the temperature close to 800 C. The temperature is measured every minute over a 2-hour period, during which time the minimum and maximum temperatures measured are 782 and 819°C. Analysis of the 120 measurements shows a mean value of 800.3 C and a mandard deviation of 7.58 C. Measurements are divided into eight data bins of 5 C width with boundaries at 780.5, 785.5, 790.5, 795.5, 800.5, 805.5, 810.5, 815.5, and 820.5. The measurement count in bin one from 780.5 to 785.5 C was 3, and the count in the other successive bins was 8, 21, 30, 28, 19, 9, and 2. Apply the χ⁻ test to see whether the measurements lit a Gaussian distribution to (a) a 90% confidence level and (b) a 95% confidence level think carefully about whether the χ⁻ test will be reliable for measurement counts observed and whether there needs to be any change in the number of data bins used for the χ⁻ test).

- 3.33. The volume contained in each sample of 10 bottles of expensive perfume is measured. If the mean volume of the sample measurements is 100.5 ml with a standard deviation of 0.64 ml, calculate the upper and lower bounds to a confidence level of 95% of the mean value of the whole batch of perfume from which the 10 samples were taken.
- 3.34. A 3-volt d.c. power source required for a circuit is obtained by connecting together two 1.5-volt batteries in series. If the error in the voltage output of each battery is specified as ± 1%, calculate the likely maximum error in the 3-volt power source that they make up.
- 3.35. A temperature measurement system consists of a thermocouple whose amplified output is measured by a voltmeter. The output relationship for the thermocouple is approximately linear over the temperature range of interest. The e.m.f./temp relationship of the thermocouple has a possible error of $\pm 1\%$, the amplifier gain value has a possible error of $\pm 0.5\%$, and the voltmeter has a possible error of $\pm 2\%$. What is the possible error in the measured temperature?
- 3.36. A pressure measurement system consists of a monolithic piezoresistive pressure transducer and a bridge circuit to measure the resistance change of the transducer. The resistance (R) of the transducer is related to pressure (P) according to $R = K_1 P$ and the output of the bridge circuit (V) is related to resistance (R) by $V = K_2 R$. Thus, the output voltage is related to pressure according to $V = K_1 K_2 P$. If the maximum error in K_1 is $\pm 2\%$, the maximum error in K_2 is $\pm 1.5\%$, and the voltmeter itself has a maximum measurement error of $\pm 1\%$, what is the likely maximum error in the pressure measurement?
- 3.37. A requirement for a resistance of 1220 Ω in a circuit is satisfied by connecting together resistances of 1000 and 220 Ω in series. If each resistance has a tolerance of ± 5%, what is the likely tolerance in the total resistance?
- 3.38. In order to calculate the heat loss through the wall of a building, it is necessary to know the temperature difference between inside and outside walls. Temperatures of 5 and 20°C are measured on each side of the wall by mercury-in-glass thermometers with a range of 0 to +50°C and a quoted inaccuracy of ±1% of full-scale reading.
 - (a) Calculate the likely maximum possible error in the calculated value for the temperature difference.
 - (b) Discuss briefly how using measuring instruments with a different measurement range may improve measurement accuracy.
- 3.39. A fluid flow rate is calculated from the difference in pressure measured across a venturi. Flow rate is given by $F = K(p_2 p_1)$, where p_1 and p_2 are the pressures either side of the venturi and K is a constant. The two pressure measurements are 15.2 and 14.7 bar.
 - (a) Calculate the possible error in flow measurement if pressure-measuring instruments have a quoted error of ±0.2% of their reading.

- (b) Discuss briefly why using a differential pressure sensor rather than two separate pressure sensors would improve measurement accuracy.
- 3.40. The power dissipated in a car headlight is calculated by measuring the d.c. voltage drop across it and the current flowing through it $(P = V \times I)$. If possible errors in the measured voltage and current values are ± 1 and $\pm 2\%$, respectively, calculate the likely maximum possible error in the power value deduced.
- 3.41. The resistance of a carbon resistor is measured by applying a d.c. voltage across it and measuring the current flowing (R = V/I). If the voltage and current values are measured as 10±0.1 V and 214±5 mA, respectively, express the value of the carbon resistor.
- 3.42. The specific energy of a substance is calculated by measuring the energy content of a cubic meter volume of the substance. If the errors in energy measurement and volume measurement are ± 1 and $\pm 2\%$, respectively, what is the possible error in the calculated value of specific energy (specific energy = energy per unit volume of material)?
- 3.43. In a particular measurement system, quantity x is calculated by subtracting a measurement of a quantity z from a measurement of a quantity y, that is, x = y - z. If the possible measurement errors in y and z are $\pm ay$ and $\pm bz$, respectively, show that the value of x can be expressed as $x = y - z \pm (ay - bz)$.
 - (a) What is inconvenient about this expression for x, and what is the basis for the following expression for x that is used more commonly?

$$x=(y-z)\pm e,$$

where $e = \sqrt{(ay)^2 + (bz)^2}$.

(b) In a different measurement system, quantity p is calculated by multiplying together measurements of two quantities q and r such that p = qr. If the possible measurement errors in q and r are $\pm aq$ and $\pm br$, respectively, show that the value of p can be expressed as $p = (qr)(1 \pm [a + b])$. The volume flow rate of a liquid in a pipe (the volume flowing in unit time) is measured by allowing the end of the pipe to discharge into a vertical-sided tank with a rectangular base (see Figure 3.21). The depth of the liquid in the tank is measured at the start as h_1 meters and 1 minute later it is measured as h_2 meters. If the length and width of the tank are I and w meters, respectively, write down an expression for the volume flow rate of the liquid in cubic meters per minute. Calculate the volume flow rate of the liquid if the measured parameters have the following values:

 $h_1 = 0.8 \text{ m}$; $h_2 = 1.3 \text{ m}$; l = 4.2 m; w = 2.9 m

If the possible errors in the measurements of h_1 , h_2 , l_1 and ware 1, 1, 0.5, and 0.5%, respectively, calculate the possible error in the calculated value of the flow rate.

3.44 The density of a material is calculated by measuring the mass of a rectangular-sided block of the material whose edges have lengths of a, b, and c. What is the possible error





Diagram for Problem 3.44,

in the calculated density if the possible error in mass measurement is $\pm 1.0\%$ and possible errors in length measurement are $\pm 0.5\%$?

3.45. The density (d) of a liquid is calculated by measuring its depth (c) in a calibrated rectangular tank and then emptying it into a mass-measuring system. The length and width of the tank are (a) and (b), respectively, and thus the density is given by

$$d = m/(a \times b \times c),$$

where *m* is the measured mass of the liquid emptied out. If the possible errors in the measurements of *a*, *b*, *c*, and *m* are 1, 1, 2, and 0.5%, respectively, determine the likely maximum possible error in the calculated value of the density (d).

3.46. The volume flow rate of a liquid is calculated by allowing the liquid to flow into a cylindrical tank (stood on its flat end) and measuring the height of the liquid surface before and after the liquid has flowed for 10 minutes. The volume collected after 10 minutes is given by

$$Volume = (h_2 - h_1)\pi (d/2)^2$$
,

where h_1 and h_2 are the starting and finishing surface heights and d is the measured diameter of the tank.

(a) If $h_1 = 2$ m, $h_2 = 3$ m, and d = 2 m, calculate the volume flow rate in m^3/min

(b) If the possible error in each measurement h_1 , h_2 , and d is $\pm 1\%$, determine the likely maximum possible error in the calculated value of volume flow rate (it is assumed that there is negligible error in the time measurement).

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CHAPTER 4

Calibration of Measuring Sensors and Instruments

4.1 Introduction 103 4.2 Principles of Calibration 104 4.3 Control of Calibration Environment 103 4.4 Calibration Chain and Traceability 107 4.5 Calibration Records 110 4.6 Summary 113 4.7 Problems 113

4.1 Introduction

We just examined the various systematic and random measurement error sources in the last chapter. As far as systematic errors are concerned, we observed that recalibration at a suitable frequency was an important weapon in the quest to minimize errors due to drift in instrument correcteristics. The use of proper and rigorous calibration procedures is essential in order to ensure that recalibration achieves its intended purpose; to reflect the importance of getting these procedures right, this whole chapter is dedicated to explaining the various facets of calibration.

We start in Section 4.2 by formally defining what calibration means, explaining how it is performed and considering how to calculate the frequency with which the calibration exercise should be repeated. We then go on to look at the calibration environment in Section 4.3, where we learn that proper control of the environment in which instruments are calibrated is an until component in good calibration procedures. Section 4.4 then continues with a review of the calibration of working instruments against reference instruments is linked by the calibration chain to national and international reference standards relating to the quantity that the instrument being calibrated is designed to measure. Finally, Section 4.5 emphasizes the importance of maintaining records of instrument calibrations and suggests appropriate formats

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4.2 Principles of Calibration

Calibration consists of comparing the output of the instrument or sensor under test against the output of an instrument of known accuracy when the same input (the measured quantity) is applied to both instruments. This procedure is carried out for a range of inputs covering the whole measurement range of the instrument or sensor. Calibration ensures that the measuring accuracy of all instruments and sensors used in a measurement system is known over the whole measurement range, provided that the calibrated instruments and sensors are used in environmental conditions that are the same as those under which they were calibrated. For use of instruments and sensors under different environmental conditions, appropriate correction has to be made for the ensuing modifying inputs, as described in Chapter 3. Whether applied to instruments or sensors, calibration procedures are identical, and hence only the term instrument will be used for the rest of this chapter, with the understanding that whatever is said for instruments applies equally well to single measurement sensors.

Instruments used as a standard in calibration procedures are usually chosen to be of greater inherent accuracy than the process instruments that they are used to calibrate. Because such instruments are only used for calibration purposes, greater accuracy can often be achieved by specifying a type of instrument that would be unsuitable for normal process measurements. For instance, ruggedness is not a requirement, and freedom from this constraint opens up a much wider range of possible instruments. In practice, high-accuracy, null-type instruments are used very commonly for calibration duties, as the need for a human operator is not a problem in these circumstances.

Instrument calibration has to be repeated at prescribed intervals because the characteristics of any instrument change over a period. Changes in instrument characteristics are brought about by such factors as mechanical wear, and the effects of dirt, dust, furnes, chemicals, and temperature change in the operating environment. To a great extent, the magnitude of the drift in characteristics depends on the amount of use an instrument receives and hence on the amount of wear and the length of time that it is subjected to the operating environment. However, some drift also occurs even in storage as a result of aging effects in components within the instrument.

Determination of the frequency at which instruments should be calibrated is dependent on several factors that require specialist knowledge. If an instrument is required to measure some quantity and an inaccuracy of $\pm 2\%$ is acceptable, then a certain amount of performance degradation can be allowed if its inaccuracy immediately after recalibration is $\pm 1\%$. What is important is that the pattern of performance degradation be quantified, such that the instrument can be recalibrated before its accuracy has reduced to the limit defined by the application.

Susceptibility to the various factors that can cause changes in instrument characteristics varies according to the type of instrument involved. Possession of an in-depth knowledge of the mechanical construction and other features involved in the instrument is necessary in order to be able to quantify the effect of these quantities on the accuracy and other characteristics of an

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The type of instrument, its frequency of use, and the prevailing environmental entitions all strongly influence the calibration frequency necessary, and because so many factors are involved, it is difficult or even impossible to determine the required frequency of instrument recalibration from theoretical considerations. Instead, practical experimentation to be applied to determine the rate of such changes. Once the maximum permissible measurement error has been defined, knowledge of the rate at which the characteristics of instrument change allows a time interval to be calculated that represents the moment in time when an instrument will have reached the bounds of its acceptable performance level. The instrument must be recalibrated either at this time or earlier. This measurement error level that an instrument reaches just before recalibration is the error bound that must be quoted in the documented specifications for the instrument.

A proper course of action must be defined that describes the procedures to be followed when an instrument is found to be out of calibration, that is, when its output is different to that of the calibration instrument when the same input is applied. The required action depends very much on the nature of the discrepancy and the type of instrument involved. In many cases, deviations in the form of a simple output bias can be corrected by a small adjustment to the instrument (following which the adjustment screws must be scaled to prevent tampering). In other cases, the output scale of the instrument may have to be redrawn or scaling factors altered where the instrument output is part of some automatic control or inspection system. In extreme cases, where the calibration procedure shows signs of instrument damage, it may be necessary to send the instrument for repair or even scrap it.

Whatever system and frequency of calibration are established, it is important to review this from time to time to ensure that the system remains effective and efficient. It may happen that a less expensive (but equally effective) method of calibration becomes available with the parage of time, and such an alternative system must clearly be adopted in the interests of cost efficiency. However, the main item under scrutiny in this review is normally whether the calibration interval is still appropriate. Records of the calibration history of the instrument will be the primary basis on which this review is made. It may happen that an instrument starts to go out of calibration more quickly after a period of time, either because of aging factors which the instrument or because of changes in the operating environment. The conditions or mode of usage of the instrument may also be subject to change. As the environmental and the conditions of an instrument may change beneficially as well as adversely, there is the possibility that the recommended calibration interval may decrease as well as increase.

4.3 Control of Calibration Environment

Any instrument used as a standard in calibration procedures must be kept solely for calibration duties and must never be used for other purposes. Most particularly, it must not be regarded as a first instrument that can be used for process measurements if the instrument normally used for

that purpose breaks down. Proper provision for process instrument failures must be made by keeping a spare set of process instruments. Standard calibration instruments must be totally separate.

To ensure that these conditions are met, the calibration function must be managed and executed in a professional manner. This will normally mean setting aside a particular place within the instrumentation department of a company where all calibration operations take place and where all instruments used for calibration are kept. As far as possible this should take the form of a separate room rather than a sectioned-off area in a room used for other purposes as well. This will enable better environmental control to be applied in the calibration instruments. The level of environmental control required during calibration should be considered carefully with due regard to what level of accuracy is required in the calibration procedure, but should not be overspecified, as this will lead to unnecessary expense. Full air conditioning is not normally required for calibration at this level, as it is very expensive, but sensible precautions should be taken to guard the area from extremes of heat or cold; also, good standards of cleanliness should be maintained.

While it is desirable that all calibration functions are performed in this carefully controlled environment, it is not always practical to achieve this. Sometimes, it is not convenient or possible to remove instruments from a process plant, and in these cases, it is standard practice to calibrate them in situ. In these circumstances, appropriate corrections must be made for the deviation in the calibration environmental conditions away from those specified. This practice does not obviate the need to protect calibration instruments and maintain them in constant conditions in a calibration laboratory at all times other than when they are involved in such calibration duties on plant.

As far as management of calibration procedures is concerned, it is important that the performance of all calibration operations is assigned as the clear responsibility of just one person. That person should have total control over the calibration function and be able to limit access to the calibration laboratory to designated, approved personnel only. Only by giving this appointed person total control over the calibration function can the function be expected to operate efficiently and effectively. Lack of such definite management can only lead to unintentional neglect of the calibration system, resulting in the use of equipment in an out-of-date state of calibration and subsequent loss of traceability to reference standards. Professional management is essential so that the accuracy of measurements is guaranteed.

Calibration procedures that relate in any way to measurements used for quality control functions are controlled by the international standard ISO 9000 (this subsumes the old British quality standard BS 5750). One of the clauses in ISO 9000 requires that all persons using calibration equipment be adequately trained. The manager in charge of the calibration function

is clearly responsible for ensuring that this condition is met. Training must be adequate and interpretent at the particular needs of the calibration systems involved. People must understand they need to know and especially why they must have this information. Successful completion of training courses should be marked by the award of qualification certificates. These ettest to the proficiency of personnel involved in calibration duties and are a convenient way of demonstrating that the ISO 9000 training requirement has been satisfied.

4.4 Calibration Chain and Traceability

The calibration facilities provided within the instrumentation department of a company provide the first link in the calibration chain. Instruments used for calibration at this level are known as working standards. As such, working standard instruments are kept by the instrumentation department of a company solely for calibration duties, and for no other purpose, then it can be manned that they will maintain their accuracy over a reasonable period of time because use-related deterioration in accuracy is largely eliminated. However, over the longer term, the d_tracteristics of even such standard instruments will drift, mainly due to aging effects in companents within them. Therefore, over this longer term, a program must be instituted for calibrating working standard instruments at appropriate intervals of time against instruments of yet higher accuracy. The instrument used for calibrating working standard instruments is known as a *secondary reference standard*. This must obviously be a very well-engineered instrument that gives high accuracy and is stabilized against drift in its performance with time. This implies that it will be an expensive instrument to buy. It also requires that the environmental conditions in which it is used be controlled carefully in respect of ambient tempenture, humidity, and so on.

When the working standard instrument has been calibrated by an authorized standards laboratory, a calibration certificate will be issued. This will contain at least the following information:

- identification of the equipment calibrated
- calibration results obtained
- measurement uncertainty
- any use limitations on the equipment calibrated
- date of calibration
- Buthority under which the certificate is issued

The emblishment of a company standards laboratory to provide a calibration facility of the result of quality is economically viable only in the case of very large companies where large instruments need to be calibrated across several factories. In the case of small to state companies, the cost of buying and maintaining such equipment is not justified. Instead, they would normally use the calibration service provided by various companies that

specialize in offering a standards laboratory. What these specialist calibration companies do effectively is to share out the high cost of providing this highly accurate but infrequently used calibration service over a large number of companies. Such standards laboratories are closely monitored by national standards organizations.

In the United States, the appropriate national standards organization for validating standards laboratories is the National Bureau of Standards, whereas in the United Kingdom it is the National Physical Laboratory. An international standard now exists (ISO/IEC 17025, 2005), which sets down criteria that must be satisfied in order for a standards laboratory to be validated. These criteria cover the management requirements necessary to ensure proper operation and effectiveness of a quality management system within the calibration or testing laboratory and also some technical requirements that relate to the competence of staff, specification, and maintenance of calibration/test equipment and practical calibration procedures used.

National standards organizations usually monitor both instrument calibration and mechanical testing laboratories. Although each different country has its own structure for the maintenance of standards, each of these different frameworks tends to be equivalent in its effect in ensuring that the requirements of ISO/IEC 17025 are met. This provides confidence that the goods and aervices that cross national boundaries from one country to another have been measured by properly calibrated instruments.

The national standards organizations lay down strict conditions that a standards laboratory has to meet before it is approved. These conditions control laboratory management, environment, equipment, and documentation. The person appointed as head of the laboratory must be suitably qualified, and independence of operation of the laboratory must be guaranteed. The management structure must be such that any pressure to rush or skip calibration procedures for production reasons can be resisted. As far as the laboratory environment is concerned, proper temperature and humidity control must be provided, and high standards of cleanliness and housekeeping must be maintained. All equipment used for calibration purposes must be maintained to reference standards and supported by calibration certificates that establish this traceability. Finally, full documentation must be maintained. This should describe all calibration procedures, maintain an index system for recalibration of equipment, and include a full inventory of apparatus and traceability schedules. Having met these conditions, a standards laboratory becomes an accredited laboratory for providing calibration services and issuing calibration certificates. This accreditation is reviewed at approximately 12 monthly intervals to ensure that the laboratory is continuing to satisfy the conditions for approval laid down.

Primary reference standards, as listed in Table 1.1, describe the highest level of accuracy achievable in the measurement of any particular physical quantity. All items of equipment used in standards laboratories as accordary reference standards have to be calibrated themselves against primary reference standards at appropriate intervals of time. This procedure is acknowledged by

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the issue of a calibration certificate in the standard way. National standards organizations minimum suitable facilities for this calibration. In the United States, this is the National Foreau of Standards, and in the United Kingdom it is the National Physical Laboratory Similar national standards organizations exist in many other countries. In certain cases, such primary reference standards can be located outside national standards organizations. For intance, the primary reference standard for dimension measurement is defined by the wavelength of the orange-red line of krypton light, and it can therefore be realized in any teboratory equipped with an interferometer. In certain cases (e.g., the measurement of temosity), such primary reference standards are not available and reference standards for calibration are achieved by collaboration between several national standards organizations who perform measurements on identical samples under controlled conditions [ISO 5725 1994] and ISO 5725-2/Cor1 (2002)].

What has emerged from the foregoing discussion is that calibration has a chain-like structure in which every instrument in the chain is calibrated against a more accurate instrument immediately above it in the chain, as shown in Figure 4.1. All of the elements in the calibration chain must be known so that the calibration of process instruments at the bottom of the chain is traceable to the fundamental measurement standards. This knowledge of the full chain of instruments involved in the calibration procedure is known as *traceability* and is specified as a must have requirement in satisfying the ISO 9000 standard. Documentation must exist that shows that process instruments are calibrated by standard instruments linked by a chain of instruments involved to national reference standards. There must be clear evidence to show that there is no break in this chain.



Figure 4.1 Instrument calibration chain
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Typical calibration chain for micrometers.

To illustrate a typical calibration chain, consider the calibration of micrometers (Figure 4.2). A typical shop floor micrometer has an uncertainty (inaccuracy) of less than 1 in 10⁴. These would normally be calibrated in the instrumentation department or standards laboratory of a company against laboratory standard gauge blocks with a typical uncertainty of less than 1 in 10⁵. A specialist calibration service company would provide facilities for calibrating these laboratory standard gauge blocks with a typical uncertainty of less than 1 in 10⁵. A specialist calibration service company would provide facilities for calibrating these laboratory standard gauge blocks against reference-grade gauge blocks with a typical uncertainty of less than 1 in 10⁶. More accurate calibration equipment still is provided by national standards organizations. The National Bureau of Standards and National Physical Laboratory maintain two sets of standards for this type of calibration, a working standard and a primary standard. Spectral lamps are used to provide a working reference standard with an uncertainty of less than 1 in 10⁶. The primary standard is provided by an iodine-stabilized helium-neon laser that has a specified uncertainty of less than 1 in 10⁹. All of the links in this calibration chain must be shown in any documentation that describes the use of micrometers in making quality-related measurements

4.5 Calibration Records

An essential element in the maintenance of measurement systems and the operation of calibration procedures is the provision of full documentation. This must give a full description of the measurement requirements throughout the workplace, instruments used, and calibration system and procedures operated. Individual calibration records for each instrument must be

Colibration of Measuring Sensors and Instru

netweet within this. This documentation is a necessary part of the quality manuexist physically as a separate volume if this is more convenient. An override style in which the documentation is presented is that it should be simple and often facilitated greatly by a copious use of appendices.

the starting point in the documentation must be a statement of what measurement been defined for each measurement system documented. Such limits are establish tencing the costs of improved accuracy against customer requirements, and also what overall quality level has been specified in the quality manual. The technic required for this, which involve assessing the type and magnitude of relevant me errors, are described in Chapter 3. It is customary to express the final measurem calculated as ± 2 standard deviations, that is, within 95% confidence limits for any of these terms, see Chapter 3).

Instruments specified for each measurement situation must be listed next. This is accurate an instruments about the proper use of the instruments concert instruments will include details about any environmental control or other special that must be taken to ensure that the instruments provide measurements of sufficient to meet the measurement limits defined. The proper training courses appropriate personnel who will use the instruments must be specified.

Having disposed of the question about what instruments are used, documentation a cover the subject of calibration. Full calibration is not applied to every measuring used in a workplace because ISO 9000 acknowledges that formal calibration processary for some equipment where it is uneconomic or technically unnecessary accuracy of the measurement involved has an insignificant effect on the overall of for a product. However, any equipment excluded from calibration procedures into must be specified as such in the documentation. Identification of equipment the category is a matter of informed judgment.

For intruments that are the subject of formal calibration, documentation must spe standard instruments are to be used for the purpose and define a formal procedure. This procedure must include instructions for the storage and handling of standard interuments and specify the required environmental conditions under which calibre performed. Where a calibration procedure for a particular instrument uses publish interuments, it is sufficient to include reference to that standard procedure in the document than to reproduce the whole procedure. Whatever calibration system is established, a procedure must be defined in the documentation that ensures its continued effective intervals. The results of each review must also be documented in a formal way.

A separate record must be kept for every instrument present in the workplace, i^{μ}

whether the instrument is normally in use or is just kept as a spare. A form similar to that shown in Figure 4.3 should be used that includes details of the instrument's description, required calibration frequency, date of each calibration, and calibration results on each occasion. Where appropriate, documentation must also define the manner in which calibration results are to be recorded on the instruments themselves.

Documentation must specify procedures that are to be followed if an instrument is found to be outside the calibration limits. This may involve adjustment, redrawing its scale, or withdrawing an instrument, depending on the nature of the discrepancy and the type of instrument involved. Instruments withdrawn will either be repaired or be scrapped. In the case of withdrawn instruments, a formal procedure for marking them as such must be defined to prevent them being put back into use accidentally.

Two other items must also be covered by the calibration document. The traceability of the calibration system back to national reference standards must be defined and supported by calibration certificates (see Section 4.3). Training procedures must also be documented,

Type of matrument: Menufacturer a part number:		Company senal number: Manufacturer's serial number:			
Location:					
Instructions for use:					
Calibration frequency:		Signature of person responsible for calibration:			
	CALIB	BATION RECORD			
Celibration date	Cal	Calibration results		Calibrated by	

Figure 4.3 Typical format for instrument record sheets.

specifying the particular training courses to be attended by various personnel and what, if any, refresher courses are required.

All aspects of these documented calibration procedures will be given consideration as part of the periodic audit of the quality control system that calibration procedures are instigated to apport. While the basic responsibility for choosing a suitable interval between calibration checks rests with the engineers responsible for the instruments concerned, the quality system auditor will need to see the results of tests that show that the calibration interval has been chosen correctly and that instruments are not going outside allowable measurement uncertainty limits between calibrations. Particularly important in such audits will be the existence of procedures instigated in response to instruments found to be out of calibration. Evidence that such procedures are effective in avoiding degradation in the quality assurance function will also be required

4.6 Summary

Proper instrument calibration is an essential component in good measurement practice, and this chapter has been dedicated to explaining the various procedures that must be followed in order to perform calibration tasks efficiently and effectively. We have learned how working instruments are calibrated against a more accurate "reference" instrument that is maintained carefully and kept just for performing calibration tasks. We considered the importance of carefully designing and controlling the calibration environment in which calibration tasks are performed and observed that proper training of all personnel involved in carrying out calibration tasks had similar importance. We also learned that "first stage" calibrations that provides inceability of the working instrument calibration to national and international reference indards for the quantity being measured, with the latter representing the most accurate indards of measurement accuracy achievable. Finally, we looked at the importance of mentaming calibration records and suggested appropriate formats for these.

4.7 Problems

- 4.1. Explain the meaning of instrument calibration.
- Explain why calibration is necessary.
- Explain how the necessary calibration frequency is determined for a measuring instrument.
- Explain the following terms:
 - (a) calibration chain
 - (b) traceability
 - (c) standards laboratory

- 4.5, Explain how the calibration procedure should be managed, particularly with regard to control of the calibration environment and choice of reference instruments.
- 4.6. Will a calibrated measuring instrument always be accurate? If not, explain why not and explain what procedures can be followed to ensure that accurate measurements are obtained when using calibrated instruments.
- 4.7. Why is there no fundamental reference standard for temperature calibration? How is this difficulty overcome when temperature sensors are calibrated?
- 4.8. Discuss the necessary procedures in calibrating temperature sensors.
- 4.9. Explain the construction and working characteristics of the following three kinds of instruments used as a reference standard in pressure sensor calibration: dead-weight gauge, U-tube manometer, and barometer.
- 4.10. Discuss the main procedures involved in calibrating pressure sensors.
- 4.11. Discuss the special equipment needed and procedures involved in calibrating instruments that measure the volume flow rate of liquids.
- 4.12. What kind of equipment is needed for calibrating instruments that measure the volume flow rate of gases? How is this equipment used?
- 4.13. Discuss the general procedures involved in calibrating level sensors.
- 4.14. What is the main item of equipment used in calibrating mass-measuring instruments? Sketch the following instruments and discuss briefly their mode of operation: beam balance, weigh beam, and pendulum scale.
- 4.15. Discuss how the following are calibrated: translational displacement transducers and linear-motion accelerometers.
- 4.16. Explain the general procedures involved in calibarting (a) vibration sensors and (b) shock sensors.
- 4.17. Discuss briefly the procedures involved in the following: rotational displacement sensors, rotational velocity sensors, and rotational acceleration sensors.
- 4.18. How are dimension-measuring instruments calibrated normally?
- 4.19. Discuss briefly the two main ways of calibrating angle-measuring instruments.
- 4.20. Discuss the equipment used and procedures involved in calibrating viscosity-measuring instruments.
- 4.21. Discuss briefly the calibration of moisture and humidity measurements.

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CHAPTER 5

Data Acquisition with LabVIEW

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5.1 Introduction

This chapter is designed to introduce the reader to the concept of computer-based data acquisition and to LabVIEW, a software package developed by National Instruments. The main reason for focusing on LabVIEW is its prevalence in laboratory setting. To be sure there are other aoftware tools that support laboratory data acquisition made by a range of vendors. These are reviewed briefly in the appendix due to their limited presence in the educational setting. We should also point out that Matlab and other software tools used to model and simulate dynamic systems are at times used in laboratory setting although their use is often limited to specialized applications such as real-time control. For this reason, these tools are not discussed in this chapter.

LabVIEW itself is as an extensive programming platform. It includes a multitude of functionalities Binging from basic algebraic operators to advanced signal processing components that can be grated into rather sophisticated and complex programs. For pedagogical reasons we only

and and harvementation: Theory and Application Bit2 (Decore Inc. All ophic reserve).

introduce the main ideas from LabVIEW that are necessary for functioning in a typical undergraduate engineering laboratory environment. Advanced programming skills can be developed over time as the reader gains comfort with the basic functioning of LabVIEW and its external interfaces.

Specific topics discussed in this chapter and the associated learning objectives are as follows.

- Structure of personal computer (PC)-based data acquisition (DAQ) systems, the purpose of DAQ cards, and the role of LabVIEW in this context
- Development of simple virtual instruments (VIs) using basic functionalities of LabVIEW, namely arithmetic and logic operations
- Construction of functionally enhanced VIs using LabVIEW program flow control
 operations, such as the while loop and the case structure
- Development of VIs that allow for interaction with external hardware as, for instance, acquisition of external signals via DAQ card input channels and generation of functions using DAQ card output channels

These functionalities are essential to using LabVIEW in laboratory setting. Additional capabilities of LabVIEW are explored in the subsequent chapter on signal processing in LabVIEW.

5.2 Computer-Based Data Acquisition

In studying mechanical systems, it is often necessary to use electronic sensors to measure certain variables, such as temperature (using thermocouples or RTDs), pressure (using piezoelectric transducers), strain (using strain gauges), and so forth. Although it is possible to use oscilloscopes or multimeters to monitor these variables, it is often preferable to use a PC to view and record the data through the use of a DAQ card. One particular advantage of using computers in this respect is that data can be stored and converted to a format that can be used by spreadsheets (such as Microsoft Excel) or other software packages such as Matlab for more extensive analysis. Another advantage is that significant digital processing of data can be performed in real time via the same platform used to acquire the data. This can significantly improve the process of performing an experiment by making real-time data more useful for further processing.

5.2.1 Acquisition of Data

One important step in the data acquisition process is the conversion of analogue signals received from sensing instruments to digital representations that can be processed by the computer. Because data must be stored in the computer's memory in the form of individual data points represented by binary numbers, incoming analogue data must be *sampled* at discrete time intervals and *quantized* to one of a set of predefined values. In most cases, this is

accomplished using a digital-to-analogue (D/A) conversion component on the DAQ card inside the PC or interconnected to it via a Universal Serial Bus (USB) port. Note that both options are used commonly. However, laptop computers and/or low-profile PCs generally require the use of USB-based DAQ devices.

5.3 National Instruments LabVIEW

LabVIEW is a software package that provides the functional tools and a user interface for data acquisition. Figure 5.1 depicts a schematic of data flow in the data acquisition process. Note that the physical system may be a mechanical system, such as a beam subjected to stress, a elemical process such as a distillation column, a DC motor with both mechanical and electrical momponents, and so forth. The key issue here is that certain measurements are taken from the given physical system and are acquired and processed by the PC-based data acquisition system.

LabVIEW plays a pivotal role in the data acquisition process. Through the use of VIs, LabVIEW directs the real-time sampling of sensor data through the DAQ card (also known as the I/O card) and is capable of storing, processing, and displaying the collected data. In most cases, one or more sensors transmit analogue readings to the DAQ card in the computer. These analogue data are then converted to individual digital values by the DAQ card and are made available to LabVIEW, at which point they can be displayed to the user. Although LabVIEW is capable of some data analysis functions, it is often preferable to export the data to a spreadsheet for detailed numbries and graphical presentation.



5.3.1 Virtual Instruments

A VI is a program, created in the LabVIEW programming environment, that simulates physical or hard instruments such as oscilloscopes or function generators. A simple VI used to produce a waveform is depicted in Figure 5.2. The front panel (shown in Figure 5.2) acts as the *user interface*, while data acquisition (in this case the generation process) is performed by a combination of the PC and the DAQ card. Much like the front panel of a real instrument, the front panel window contains *controls* (i.e., knobs and switches) that allow the user to modify certain parameters during the experiment. These include a selector to choose the type of waveform and numerical controls to choose the frequency and amplitude of the generated waveform, as well as its phase, amplitude and offset.

The front panel of a VI typically also contains *indicators* that display data or other important information related to the experiment. In this case, a *graph* is used to depict the waveform. The block diagram (not shown but discussed later) is analogous to the wiring and internal components of a real instrument. The configuration of the VI's block diagram determines how front panel controls and indicators are related. It also incorporates functions such as communicating with the DAQ card and exporting data to disk files in spreadsheet format.

5.4 Introduction to Graphical Programming in LabVIEW

LabVIEW makes use of a graphical programming language that determines how each VI will work. This section discusses the inner workings of a simple LabVIEW VI used to add and subtract two numbers. While this VI is not particularly useful in a laboratory setting, it

Waveform	Bignal Craph
Frequency (Hz) Amplitu 3 2 Amplitude Offset (V) Human 10.00 0.00	

Figure 5.2 A simple function generator virtual instrument.

illustrates how basic LabVIEW components can be used to construct a VI and hence helps the reader move towards developing more sophisticated VIs. Figure 5.3 shows the front panel and block diagram of the VI, which accepts two numbers from the user (X and Y) via two simple numeric controls and produces the sum and difference (X + Y and X - Y) of the numbers displaced on the front panel via two simple numeric indicators.

The block diagram of the VI is a graphical, or more accurately a *data flow*, program that defines how the controls and indicators on the front panel are interrelated. Controls on the front panel of the VI abov values that can be modified by the user while the VI is operating. Indicators display values that are output by the VI. Each control and indicator in the front panel window is associated with a *terminal* in the block diagram window. Wires in the block diagram window represent the flow of data within the VI. *Nodes* are additional programming elements that can perform operations on variables, perform input or output functions through the DAQ card, and serve a variety of other functions as well.

The two nodes in the VI shown in Figure 5.3 (add and subtract) have two inputs and one output, as for instance is depicted in Figure 5.4. Data can be passed to a node through its input terminals (usually on the left), and the results can be accessed through the node's output terminals, usually on the right.



Figure 5.3 Addition and subtraction VI.

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Figure 5.4 The add node.

Because LabVIEW diagrams are data flow driven, the sequence in which the various operations in the VI are executed is *not* determined by the *order* of a set of commands. Rather, a block diagram node executes when data are present at all of its input terminals. As a result, in the case of the block diagram in Figure 5.3, one does not know whether the add node or the subtract node will execute first. This issue has implications in more complex applications but is not particularly important in the present context. However, one cannot assume an order of execution merely on the basis of the position of the computational nodes (top to bottom or left to right). If a certain execution order is required or desired, one must explicitly build program flow control mechanisms into the VI, which in practice is not always possible nor is it in the spirit in which LabVIEW was originally designed.

5.4.1 Elements of the Tools Palette

The mouse pointer can perform a number of different functions in the LabVIEW environment depending on which pointer tool is selected. One can change the mouse pointer tool by selecting the desired tool from the tools palette shown in Figure 5.5. (If the tools palette does not appear on the screen, it can be displayed by selecting Tools on the View menu.)

Choices available in the tools palette are as follows:

- × ==
 - Automatic tool selection. Automatically selects the tool it assumes you need depending on context. For instance, it can be the positioning tool. the wiring tool, or the text tool as further noted later.
 - *Operating tool.* This tool is used operate the front panel controls before or while the VI is running.
 - Positioning tool. This tool is used to select, move, or resize objects in either the front panel or the diagram windows. For example, to delete a node in a diagram one would first select the node with the positioning tool and then press the delete key.
- · 14
- Text tool. This tool is used to add or change a label. The enter key is used 10 finalize the task.
- Wiring tool. This tool is used to wire objects together in the diagram window. When this tool is selected, you can move the mouse pointer over one of a node input or output terminals to see the description of that terminal.



Figure 5.5 The tools palette.

One can add controls and indicators to the front panel of a VI by dragging and dropping them from the controls palette depicted in Figure 5.6 and which is visible *only* when the front panel mindow is *active*.

If, for some reason, the controls palette is not visible, one can access it by right clicking anywhere in the front panel window. Once a control or indicator is added to the front panel of a VI, the corresponding terminal is created automatically in the block diagram window. Adding additional nodes to the block diagram requires use of the *functions palette*, which is accumible once the block diagram window is visible. One can add arithmetic and logic elements to the block diagram window by dragging and dropping these elements from the functions palette. The functions to add, subtract, and so on can be found in the numeric infiniteties of the programming section of the functions palette (Figure 5.7, the fourth icon from the left). One can also use constants from the numeric subpalette in a block diagram and the functions as inputs to various nodes.

5.5 Logic Operations in LabVIEW

In more nomplex VIs, one may encounter situations where the VI must react differently depending on the condition at hand. For example, in a data acquisition process, the VI may need to numeric a warning light when an input voltage exceeds a certain threshold and therefore it may

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be necessary to compare the input voltage with the threshold value. In addition, the VI needs to make a decision based on the result of the comparison (turn on a light on the screen or external to the DAQ system, produce an alarm sound, etc.). To allow for these types of applications, many logic operators are available in LabVIEW. These can be found in the comparison subpalette of the programming section of the functions palette. Note that as stated earlier, the functions palette is available when the diagram window is the top (focus) window on the screen. If one needs to identify the comparison subpalette, one can move the mouse pointer over the programming section of the palette to call out the different subpalettes.

Comparison nodes, as, for instance, depicted in Figure 5.8, are used to compare two numbers. Their output is either *true* or *false*. This value can be used to make decisions between two numbers as shown in Figure 5.8. Another important node in this respect is the *select* node, which is also available in the same subpalette. This node makes a decision based on the outcome of a *previous* comparison, such as depicted in Figure 5.8. If the select node's middle input is true, it selects its top input as its output. If its middle input is false, it selects its bottom input as its output. In this way, one can pair the comparison nodes with a select node to produce an appropriate action for subsequent processing.

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Figure 5.8 Logic example

5.6 Loops in LabVIEW

In building more sophisticated VIs it wall not be sufficient to simply perform an operation once. For example, if LabVIEW is being used to compute the factorial of an integer, *n*, the program will recent to continue to multiply *n* by $n - l_{\infty}$, n - 2, and so forth. More pertinently, in data acquisition process to acquire multipline samples of data and process the data. For this reason,



Example loop VI.

LabVIEW includes several types of loop structures. These can be found in the structures subpalette of the programming section in the functions palette. (Note that as with every one of LabVIEW's tools, one can use LabVIEW's help feature or its quick help feature to get more information on these constructs.) Here the user can find a *while* loop, a *for* loop, a *case statement*, and several other important loop structures. Figure 5.9 depicts a simple program that utilizes a loop There are several important items to note about using loops. Everything contained inside the loop will be repeated until the *ending condition* of the loop is met. For a *while* loop, this will be some type of logical condition. In our example given earlier, we have used a button to *stop* the loop. The loop will stop when a value of *true* is passed to the stop button at the completion of the loop.

In addition, it is often important to be able to pass values from one iteration to the next. In the example given previously, we needed to take the number from the last iteration and add one to it. This is accomplished using a *shift register*. To add a shift register, one has to right click (or option click on a Mac) on the right or left side of the loop and use the menu that opens up to add the shift register. To use the shift register, one must wire the value to be passed to the next iteration to the right side as shown in Figure 5.9. To use the value from the previous iteration, one draws wire from the left side of the loop box to the terminal of one's choosing. In addition, elements initially wired together can be included in a loop simply by creating one around these elements. The wiring initially in place will be preserved. Finally, note that the metronome in the loop times the loop so that it runs every 100 ms. This element is available from the timing subpalette in the programming section of the functions patlette

5.7 Case Structure in LabVIEW

The case structure is a programming construct that is useful in emulating a switch, similar to what appears on the front panel of a hard instrument to allow the user to select one of multiple available tasks. In terms of its appearance in LabVIEW, a case structure works much like a while loop as evident in Figure 5.10. However, significant differences exist between a case



A case structure in LabVIEW.

Bructure and a while loop in that a case structure performs a *separate* operation for each case of the conditional statement that drives this structure. The conditional statement takes a value chosen by the user at runtime from among the set of values for which the given case structure is pogrammed to execute. This set can be {0,1}, as is the case initially when a case structure is added to a VI, and can be expanded during the programming stage by right clicking on the maditional statement and choosing "Add case" as necessary. For each case, the VI must include an appropriate execution plan that is placed within the bounding box of the case structure. The maditional statement associated with a case structure is typically driven by a *ring*, which is placed on the front panel of the given VI and appears outside the bounding box of the case structure in the block diagram panel of the VI.

This ring is connected to the question mark box on the right side of the case structure in the block diagram. This is illustrated in Figure 5.11 in conjunction with a four-function calculator implemented in LabVIEW. It is evident in Figure 5.11 that the *ring*, acting as an operation selector, drives the condition statement, whereas variables X and Y, implemented via numerical controls on the front panel, pass their value to the case structure, which embeds the actual mathematical operation for each of the four functions (add, subtract, multiply, and divide) in a dedicated panel. Figure 5.11 depicts the panel associated with the divide operation. Arrows in the condition statement of the case structure can be used during the programming stage to open each of the cases that the case structure is intended to implement. The ring outside the case structure must have as many elements as there are cases in the respective case structure. Here, it is important to make sure that a structure is in the first option in the ring is "add," the first function of the case structure to implement the addition function. Exercise 5.6 deals with this issue at more intended to account the case structure of the case with other LabVIEW elements, right clicking on a given element interded to view a detailed description and examples associated with that element.

5.8 Data Acquisition Using LabVIEW

perform data acquisition tool. The typical setup in the laboratory is shown in perform data acquisition and monitoring tasks, a terminal box is needed to obtain the input from sensors and to allow a way to produce output voltages from the data acquisition card.





Figure 5.31 A menu ring used in conjunction with a case structure.



Figure 5.12 A typical setup for LabVIEW-based data acquisition.



Figure 5.13 A NI BNC-2120 connector block

A typical connector block is shown in Figure 5.13. This is National Instrument BNC-2120. Pin numbers and the style of the terminal box will vary depending on the model being used. The experiments described later in this chapter use BNC-2120, but several will use different imminals. For the exercise discussed below the data acquisition card's differential mode is used, minimum that it reports the voltage difference across a channel (channel 0 in our case). The card can also operate in an absolute mode where it references the reading to the ground level. Finally, there is one last piece of equipment, which will be needed in the subsequent discussion: the limition generator, which can be seen in Figure 5.13.

As the name suggests, this piece of equipment is used to generate a sine wave, a triangle wave, or a square wave. The amplitude of the wave can be adjusted by using the amplitude knob. The fraggency of the wave can also be adjusted using the relevant buttons. The main use of this true in the present context is to produce an external input to a custom VI that is shown in figure 5.14, which converts the voltage produced by the function generator into a temperature reading in Celsius and Fahrenheit units.

The board ID and channel settings specify information about the DAQ card that tells VI where to look for data. The algebraic operations that implement the conversion of data more or less straightforward as depicted in Figure 5.14.

5.9 LabVIEW Function Generation

In this section we will create a VI that emulates a function generator, that is, the VI should produce a periodic signal with a user-selected shape, frequency, and amplitude to an output time on the National Instruments DAQ card. In addition, the user should be able to select



Figure 5.14 Thermometer VI.

the resolution of the waveform (i.e., the number of data points per period). The VI's front panel should also include a waveform graph that displays at least one period of the waveform selected as it appears in Figure 5.15.

The VI produces a sine wave, triangle wave, or square wave as selected by the user. This requires that a case structure be wrapped around the signal generation block and a ring block to communicate between the front panel and the case structure. This is discussed further in the LabVIEW exercises at the end of the chapter.

5.10 Summary

This chapter was meant to introduce the reader to the usage of LabVIEW in computer-based data acquisition. Basic LabVIEW programming concepts, namely controls, indicators, and simple nodes used to implement algebraic operations, as well as program flow control

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Figure 5.15 Function generator front panel,

constructs, that is, while loop and case structure, were introduced. These building blocks were used to implement increasingly more complex LabVIEW VIs. These VIs can be used as mind-alone LabVIEW programs or expanded to form sophisticated VIs in conjunction with inditional LabVIEW elements. These include signal processing tools, which are discussed in the subsequent chapter. The exercises that follow enable the reader to practice innerstructure a number of VIs that are of value in a laboratory setting.

5.11 Problems

5.1. In order to demonstrate your understanding, build the VI found in Figure 5.3. To get marted, click on the LabVIEW icon found on the defktop of your computer (assuming it is previously installed). This should pop up a window with several choices. Select "Blank VI" and click "OK." From here you should see the front panel (it is gray). To open the block diagram window go to the window and then the show block diagram option (Ctrl-E or Cmd-E also do the same). On the front panel, you will need to add the required numeric controls for X and Y and numeric indicators for X + Y and X - Y. These are available in the modern subpalette of the controls palette, which is available by right clicking in the front panel. You will then use the block diagram window and implement the add and subtract mates (available in the numeric section of the programming marked the diagram window) and connect them to the appropriate controls and indicators. Note that you can change the labels of each entity by using the test tool from the tools palette. Changing the label of an indicator or control in the block diagram window to get its label in the front panel as well. Once you have inserted the necessary nodes

and wired them together properly, you can run the VI by pressing the run batton (2) at the upper left corner of the front panel window. The digital indicators should then display the results of the addition and subtraction operations. You can also use continuous run batton (2), which is next to the run button.

- 5.2. Create a program that will take the slope of a line passing between any two points, in other words, given two points, (X_1, Y_1) and (X_2, Y_2) , find the slope of the line, Y = mX + b, that passes through these points. This program should have four digital inputs (as numeric controls) that allow the user to select the two coordinates. It should have one digital indicator that provides the value of the slope of the line between them.
- 5.3. Using ideas similar to those in Figure 5.8, demonstrate your understanding of the logic operations by adding an additional indicator that will display the greater of the two numbers determined from your addition and subtraction operations in Exercise 5.1. Is the number obtained by the addition operation always the greatest?
- 5.4. Demonstrate your understanding of logic operations by building a VI that takes as input three numbers and outputs the greatest and the smallest value of the three. This will involve very similar logic operations to the one performed in the earlier VI.
- 5.5. After you have had a brief exposure to the operation of loops and other structures in LabVIEW, practice by creating the program from Figure 5.9. When fully operational, the program should continue to increment by a counter 1 every 0.1 seconds until the step batton is pushed. Vesify that this is true and that waiting longer to press the step battom results in a larger number. What is the difference between staide and outside lasp displays? Why do you think this happens? If you let the program run and forgot to turn it off when you left the lab, would your program ever be able to reach infinity? Explain your answer.
- 5.6. The specific task that you will perform is to create a calculator that will add, subtract, raultiply, or divide two numbers using a case structure as depicted earlier in Figure 5.11. This will requise you to use two inputs, an output, and a ring on the front panel. You will need a case structure in the diagram window, which initially will have only two cases {0,1} but these can be extended by right clicking on the condition statement in the block diagram. The case structure itself can be found in the structures subpalette of the functions palette. The ring should be added to the front panel of the VI and can be found on the modern subpalette of the controls palette. The properties dialog box of the ring, which opens up by right clicking on the ring, allows you to add cases as you need (in the case, four cases). Make sure the order of the list on the ring corresponds to the case list.
- 5.7. Data acquisition is probably the most important aspect of LabVIEW. To be able to understand completely what takes place when you are taking data, it is important to know what takes are performed by a VI that acquires data from an external source. The VI introduced earlier in Figure 5.14 takes a temperature measurement every time the run button is pushed. While this is useful for taking measurements where temperature is constant (e.g., soon temperature), it is not useful in tracking temperature changes.

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(The next exercise addresses this issue via a loop structure.) If a low-frequency square wave is used, however, it is possible to verify that the VI functions as intended. Connect a function executor to the DAQ card. Make sure that the function generator is not to produce a summe wave and that the frequency is not to be about 0.1 Hz. You may wish to view the signal on an oscilloscope to ensure that the function generator is indeed producing the desired waveform. This can be done by connecting the output of the function generator via a BNC connector to Channel A (or Channel |) on a typical two-channel scope. Be sure to set the tringer mode to external (EXT) and choose Channel A (or Channel 1) as the trigger source. You may have to initially use the ground function of the scope to ensure that the beam is accord at the midlevel of the screen and that the vertical and horizontal scales are not up properly. The same BNC connector can be used to connect the function generator to the RNC-2120, which acts as the interface between the DAQ card and the function generator.

- 5.8. In this exercise we need to add a loop to the VI from the previous exercise so that the VI can take readings continuously until a stop button on the front panel of the VI is pushed and the VI is stopped. The loop construct is in the structure subpalette of the programming acction of the functions palette. You can also find the stop button in the Boolean subpalette of the classic section of the controls palette. Verify that this works and watch how the temperature reading changes with time. Change the frequency of the function generator and observe the effects of the output. What difficulties arise when the frequency is too fast relative to the timing capacity of the loop? If we had no digital indicator, only thermometers, would this be a problem?
- 5.9. In this exercise, we will add more functions to the VI from the previous exercise. If we only want to maintain some temperature (e.g., in a thermostat), we might only care about the highest value of the temperature. Use the logic operators to determine the highest temperature of all the measurements (hint: you will need a shift register). In LabVIEW. there are many different options for data types (scalar, dynamic data, waveform, stc.). For this part of the experiment, you will need to convert from the dynamic data to a single scalar. To do this, right click in the block diagram and select express, signal manipulation, from DDT. Then place the block, select single scalar, and then click OK.

This VI gives a little more insight into data acquisition with LabVIEW and some of the difficulties that may arme. With this VI, will you be able to tell how temperature changes as a function of time? What could we do to solve this problem (in general)? What are some of the problems with the various output styles that we have considered? What might be some more hemeficial ideas?

\$10. Based on the function generator in Figure 5.15, random noise should be added to the signal by means of the "add noise" option of the signal simulation block, in the signal analysis inclines. The cutput from the function generator should be added to the noise using an addition block, as it can add both signals and constants. Send this noisy signal to a new waveform graph. In order to extract the original signal from the noisy signal, a filter will be

applied. The filter reduces the effect of portions of the signal that are above a specified frequency. This allows us to remove the high-frequency noise. The filter block can be found in the signal analysis toolbox. Configure the filter to remove noise from the signal. Your front panel window should look much like Figure 5.16,

Select three sets of operating conditions (i.e., amplitude and frequency) for the triangle wave pattern and measure the actual amplitude and frequency of the waveform shown on the oscilloacope. This will require you to connect the DAQ board to the scope inputs using BNC cables. Verify that your measured amplitudes and frequencies are the same as those you input to the VI. Vary the noise amplitude between 0 and twice the signal amplitude and take acreen captures of the results.

5.12 Appendix: Software Tools for Laboratory Data Acquisition

5.12.1 Measurement Foundry

Measurement Foundry is produced by Data Translation and has significant capabilities for rapid application development in conjunction with DT-Open Laters for .NET class library and compliant hardware. It offers the ability to acquire, synchronize, and correlate data and to perform control loop operations, it also features automatic documentation of programs and links with Excel and Matlab.



Figure 5.16 Function generator and litter front panel.

5.12.2 Dasylad

DesyLab from Measurement Computing Corporation (MCC) allows for the integration of prophecal functions, real-time operations, including PID control, and real-time display via charts, meters, and graphs, and incorporates an extensive library of computational functions. It provides serial, OPC, ODBC, and network interface functions and supports data acquisition bardware from MCC, IOtech, and other vandors.

5.12.3 INET-IWPLUS

This software, sold by lomega, which is also a distributor of DAQ cards and sensors, can be used to generate analogue and digital output waveforms and run faedback/control loops, such as FID, and has capabilities similar in concept to LabVIEW, which allow for the creation of concept virtual instruments.

5.12.4 WinWody

Win Wedge is yet another data acquisition software that uses a Microsoft Windows Dynamic Data Exchange mechanism to provide data acquisition and instrument control in conjunction with Microsoft Excel, Access, and so on. It provides a menu-driven configuration program and is used manually in conjunction with serial data anesass.



CHAPTER 6

Signal Processing with LabVIEW

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6.1 Introduction

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Analogue and digital filters are used extensively in active signal processing. In this chapter, both of these topics are discussed and examples using LabVIEW are presented. The main nue of these signal-processing techniques is in pre- and postprocessing of memor signals. In Princedar, analogue filters are often used to deal with the so-called aliasing phenomenon that a common in data acquisition systems. Digital filters are generally used to postprocess disgnals and can be used in conjunction with sophisticated digital signal processing techniques such as Past Fourier Transform to perform spectral analysis of acquired signals where its mind, the chapter introduces the reader to the following topics:

Analogue filters, their analysis, and synthesis using passive components (resistors and sepactors) as well as active components (operational amplifices),

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- Frequency response of a low-pass filter using Bode plots, illustrating the response of the filter with varying frequency of the input signal.
- The concept of a digital filter as counterpart to the analogue filter and built using software.
- Implementation of moving average (MA) and autoregressive moving average (ARMA) model-based digital filters and their implementation in LabVIEW.
- Using LabVIEW to develop virtual instruments (VIs) that implement digital filters and demonstrate their functioning using a graphical display of pre- and postfiltered signals.

These learning objectives are illustrated through detailed descriptions, examples, and exercises. The presentation refers to supporting hardware from National Instruments and other manufacturers (namely Analog Devices, a maker of micromechanical accelerometers and amiliar microelectromechanical components used as sensors in measurement and instrumentation).

The reader is expected to have access to a laboratory environment that allows for implementation of analogue filters via passive and active electronic components, test instruments such as ancilloncopes and function generators, and, more importantly, access to LabVIEW for implementation of the virtual instruments discussed in the sequel. Use of a small inexpensive fm, which can be the basis for studying the impact of rotor imbalance and vibration that is filtered with a combination of analogue and digital filters, is also meful. Other sources of real data can be used, however, so long as the measured signal manifests a combination of "good" and "bad" information, preferably at low and high frequencies, respectively, which can be used as the basis for the experimental component of the examples and exercises discussed in this chapter. It is possible, however, to produce virtual sensor data using LabVIEW itself, as it is done in several of the examples. to illustrate signal processing techniques, although it is always important to use real data at some point in the process of learning to apply nignal-processing techniques.

6.2 Analogue Filters

Analogue filters are used primarily for two reasons: (i) to buffer and reduce the impedance of sensors for interface with data acquisition devices and (ii) to eliminate high-frequency noise from the original signal so as to prevent *aliazing* in analogue-to-digital conversion. Analogue filters can be constructed using passive components (namely senistors, sapacities, and, at times, inductors) or via a combination of passive and active components (transisters or, more commonly, operational amplifiers) leading to active filter designs. We consider both cases here.

6.2.1 Passive Filters

Passive filters are designed with a few simple electronic components (resistors and capacitors). The basic *low-pass* filter, depicted in Figure 6.1, can be used to remove (or attenuate) the frequency noise in the original signal, in this case denoted by v_i . The underlying is that any time function can be viewed as being a combination of simuoidals. More exactly, any periodic function of time is approximated by an infinite series of unusoidals at frequencies that are underlying of the so-called fundamental frequency of the original signal the m-called spectral context of the signal). Nonperiodic functions can be viewed in meterically the same way but we must allow for a continuous spectrum. For example, the magnal signal, v_i , may be approximated by

$$v_{i} = V_{i,j} \sin(\omega t) + V_{i,j} \sin(2\omega t) + V_{i,j} \sin(3\omega t) + \cdots$$
(6.1)

where $V_{1,2}, V_{1,2}, V_{1,3}, \ldots$ are the amplitudes of the connecutively higher frequency components or formation of the original signal.

These higher frequency components may represent fluctuations (or, in many cases, electrical noise) that we may wish to attenuate to prevent aliasing (appearance of high-frequency components in the analogue signal as low-frequency alianes of these components) and generally to present a clean signal to the DAQ system. The filter in Figure 6.1 produces an output, v_{en} which has the *same set* of components (in terms of the respective frequencies) as the original again, v_{e} , but at reduced amplitudes;

$$v_{o} = V_{o,1} \sin(\omega t) + V_{o,2} \sin(2\omega t) + V_{o,3} \sin(3\omega t) + \dots$$
(6.2)

where $V_{n,1}, V_{n,2}, V_{n,3}, \ldots$ are the amplitudes of the sinusoidal components in $V_{n,1}$. In general, $V_{n,1}$, $V_{n,2}, V_{n,3}$, ..., are smaller than their counterparts in the input signal, $V_{i,1}, V_{i,3}, V_{i,3}, V_{i,3}, \ldots$. For instance, depending on the values of R and C in the filter shown in Figure 6.1, $V_{n,1}$ may be very close to $V_{i,1}$, say 98% of this value, but $V_{n,2}$ may be about 70% of $V_{i,3}$ and to forth. The reason for this is that the given low-pass filter attenuation (hence the smaller the amplitude of the given frequency; the larger the attenuation (hence the smaller the amplitude of the given in the output signal). The precise amount of attenuation can be found from the intermet response graph of the filer (countroally referred to as its Bode plot) as, for more depicted in Figure 6.2,



Passive low-pass filter.



The specific equation for the filter from the application of Kirchoff's current law at the output node (assuming an open circuit or no load at the output) is given by

$$\frac{v_1 - v_n}{R} + C \frac{d}{dt}(v_n) = 0.$$
(6.3)

This can be simplified into

$$RC\frac{dv_{\sigma}}{dt} + v_{\sigma} = v_{i}.$$
(6.4)

As a first-order differential equation, it can be transformed into transfer function form, using Laplace transform, as

$$\frac{\dot{V}_{a}}{V_{b}} = \frac{1}{14 + 1}$$
, (6.5)

where x = RC is the time constant of the filter, that is, essentially the time it takes for the filter 10 respond to a step input function by reaching 63% (almost two-thinks) of its steady-state output

The inverse of r, that is, $\omega_c = 1/\tau$, is known as the corner frequency of the filter, that is, is frequency above which the filter starts to attenuate its input. These are discussed further below in the context of the no-called *Bode plot* of the filter. Assuming sinusoidal functions of the form $v_i = V_i(\omega t)$, whose Laplace transform is given by

$$\bar{v}_i = \frac{\omega V_i}{s^2 + \omega^2},$$
(6.6)

and substituting in Equation (6.6), taking partial fractions and simplification (including dropping the transient response term as detailed in the appendix), the steady-state output would $v_{\alpha} \approx V_{\alpha} \sin(\omega t + \omega)$, where

$$\frac{V_{a}}{V_{i}} = \frac{1}{\sqrt{(\pi\omega)^{2} + 1}}$$
 and $\phi = -\tan^{-1}(\pi\omega)$. (6.7)

in more standard form, we have

$$\frac{V_o}{V_i} \bigg|_{ab} = 20 \log \frac{1}{\sqrt{(\tau \omega)^2 + 1}} = 20 \log 1 - 10 \log ((\tau \omega)^2 + 1)$$
(6.8)

$$\frac{V_{\sigma}}{V_{t}} = \begin{cases} 0 & \tau \omega << 1 \\ -20 \log \tau \omega & 1 << \tau \omega \end{cases}$$
(6.9)

The graph of the V_{o}/V_{o} is precisely what was depicted earlier in Figure 6.2 where it is evident that the frequencies, particularly those higher than the corner frequency of 10 t/s, are attenuated at a more standing rate, leading to the reduction of high-frequency components in the filtered signal.

6.2.2 Active Filters Using Op-amps

The passive filter shown previously is simple and can, in principle, be used to filter out instantable components of a given signal. However, because it is made up of entirely passive components (resistors and capacitors), it has to draw current from the input and will, in addition, the circuit connected to the output of the filter. Op-amps can eliminate this problem, as instantent that is drawn from the input stage in very small (because op-amps have large internal means of the order of 10 MΩ). Likewine, as active devices, op-amps supply current to their output and hence minimize the impact of the filter on any output circuit, such as the DAQ and, thereby less affecting the reading of the acquired signal. With this in mind, op-amps clien used in conjunction with resistors and capacitors to cruste an active filter. A sample imparation is given in Figure 6.3,

To be able to utilize this cancel, we must determine the relation between the input v_i and the convert v_i . The manufactor of currents of the inverting input is given by



 $\frac{v_{1}-v_{-}}{R_{1}}+\frac{v_{0}-v_{-}}{R_{2}}+C\frac{d}{dt}(v_{e}-v_{-})=0.$

Now, given that in a negative feedback configuration as shown earlier, $v_{-} = v_{+} = 0$, we can simplify this to

$$\frac{v_l}{R_1} + \frac{v_o}{R_2} + C \frac{d}{dt}(v_o) = 0.$$

We can rewrite this as

$$v_o + R_2 C \frac{d}{dt} (v_o) = -\frac{R_2}{R_1} v_i.$$

This is very similar to a passive filter equation, with the exception of the gain on v_i . The negative sign means that the filtered signal will lag at least 180 degrees behind the unfiltered one. (This issue can be resolved via an inverting filter of gain of -1.) We can call this gain A, so $k = R_2/R_1$. In addition, we see that the time constant is given by $\tau = R_2C$. So, we have two degrees of freedom in our filter configuration. We may adjust the gain constant, k, to amplify low-frequency signals. However, this will also raise the value of the crossover frequency and therefore allow noise to have a higher amplification. In addition, we can change the corner frequency ($\omega_c = 1/\tau$) by adjusting the relevant parameters. This will have effects on the gain well, which must be taken into account. These can be better understood by examining the system in the frequency domain. In the frequency domain, the ratio of the output to the imput voltage is given by

$$\frac{V_{V_{1}}}{V_{1}} = 20 \log \frac{1}{\sqrt{(\tau \omega)^{2} + 1}} = 20 \log t - 10 \log((\tau \omega)^{2} + 1)$$

$$\frac{V_{1}}{V_{1}} = \begin{cases} 20 \log t & \tau \omega << 1 \\ 20 \log t - 20 \log t & 1 << \tau \omega \end{cases}$$

We can understand better how the filter works by examining the Bode plot of the system, which is indeed similar to that in Figure 6.2, with the only exception being an upward shift of the graph by 20 togs. As discussed earlier, the graph is meant to illustrate how the filter passes through arganis of frequency up to its corner frequency and gradually attenuates those beyond this level as depicted in Figure 6.2.

6.2.3 Implementation on a Broadboard

is a laboratory setting, one can build and test various circuits, including low-pass filters using breadboards. Figure 6.4 depicts one such breadboard made by National Instruments (NI). Similar boards with more or less additional features are available from various manufacturers. This particular breadboard has a connector (lower left corner) that attaches readily to an NI DAQ card. Other breadboards are also available from NI and other manufacturers.

6.2.4 Building the Circuit

Assuming access to a breadboard similar to Figure 6.4, circuits can be built on the white section of the breadboard. The horizontal vections of holes in the wider strips of this pection are connected together to allow placement of circuit components that may have



Figure 6.4 Breadboard for filter implementation

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different sizes, while the thinner sections provide a mechanism for access to power and ground (or common signals). In addition, as stated earlier, this particular board has the ability to interface with the data acquisition cmd. Inputs and outputs from the card can be taken from the pins shown in Figure 6.4 and connected either to the breadboard or to external devices.

6.2.5 Electronic Components

A variety of electronic components are used to build analogue filters with resistors, capacitors being the most common types. Resistors can be either fixed or variable. As the name implies, a fixed resistor has one resistance value and cannot be changed. A variable resistor, however, can be adjusted to have different values. Resistors are coded by color as shown in Figure 6.5.

×.



Figure 6.5 Resistor color-coding scheme

Band 1	Bund 2	Band 3	A to it iptim	Televene	Value
Orange	Orange	N/A	Brown	Brown	330 Q ± 1%
Blue	Grey	Black	Green	Illue	66 MQ ± 0.25%
Block	Green	Green	Red	Red	5500 Q ± 2%
Rod	White	Yellow	Gold	Violet	29.4 Q ± 0.7%

Table 6.1 Example Resistors

Note that colors may not be evident but this same figure is generally available online at a number of sources.

Note that not all resistors have the same number of bands, so it is important to know the type of posistor at hand. If a resistor has only four bands, then it does not have the third digit. A few murphes are illustrated in Table 6.1.

In addition to resistors, capacitors are used in building analogue filters. A picture of a ceramic place capacitor is shown in Figure 6.6. Unlike resistors, capacitors have their value explicitly prated on them. Capacitance values can usually be read off in either a picofarad (μF) scale or a microfarad (μF) scale. Intermediate acales are used very soldom. In addition, it is important to note that a capacitor has some parasitic resistance as well, although this is mustly very small.

Really, op-amps are key components of analogue filters. A picture of a typical op-amp, LM 741, is depicted in Figure 6.7. It is important to be sure that the connect pins are used when connecting the op-amp. The data sheet for the device, generally available from the manufacturer, punides detailed specifications in this regard.



Ceramic plate capacitor.

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Operational amplifier in DIP package.

6.2.6 Op-amps in Analogue Signal Processing

As stated earlier, op-amps can be used to perform simple or more complex tasks. For instance, as shown in Figure 6.8, to add two signals, v_i and v_o together, as op-amp and three resistors are used. This can be useful, for instance, is adjusting for a d.c. offset in an accelerometer signal or similar cases. If we were to derive the selationships between the inputs, we would arrive at the following:

$$v_{ii} = -\frac{R_2}{n}(v_i + v_r).$$

Therefore, if we set v_r to be the negative value of the DC offset from the accelerometer, we will be able to remove this offset successfully.





Offset removal and low-pass filtering.

More importantly, we will generally need to remove high-frequency noise in the sensor right prior to sampling the signal with an A/D converter. For this reason, the combination of co-amps in Figure 6.9 is used.

In practical implementation, color coding the wiring is helpful in preventing confusion. Typically the coding acheme uses red, positive supply voltage; black, ground; and blue, signal, Other colors are used to supplement these and differentiate the different signals. Exercise 6.1 refers to this in more detail in the context of performing a simple acceleration measurement experiment.

6.3 Digital Filters

Description of the second seco

6.3.1 Input Averaging Filter

In the invertiging filter, the previously unfiltered values of the given signal are used in the This filter takes the form of

$$y_t = \alpha u_t + (1 - \alpha) u_{t-1},$$
 (6.10)




Diagram of a digital filter.

Note that we can write $a_0 \equiv a$ and $a_1 \equiv 1 - a$ and hence write the above as

$$y_k = a_0 a_k + a_1 a_{k-1}$$
 (0.13)

and thus further extend this formulation to more complex filters such as

$$y_k = u_0 u_k + u_1 u_{k-1} + u_2 u_{k-2} + \dots + u_n u_{k-n}.$$
 (0.12)

This general form is called a *moving average* filter, as it is effect averages past values of the input signal, each with its respective weight. Selection of these weights is often an issue and can be formalized, although in the present context we will deal with simpler cases in which an intuitive approach to selecting these values can be used.

6.3.2 Filter with Memory

In a filter with memory, previously filtered values are used to adjust the new output. This filter takes the form

$$\mathbf{y}_k = \alpha \mathbf{u}_1 + (1 - \alpha) \mathbf{y}_{k-1},$$

where u is the weight on the current value of the unfiltered signal, u_0 . The remainder is from the previous value of the filtered signal, y_{d-1} . Varying α will change the extent to which the input signal is filtered. In particular, a relatively large u weighs in the current value of the input signal, while a small α weighs in the past (filtered) signal, y_0 . Normally, $\alpha \leq 1$. This is evident in the following example.

6.3.3 Example

A set of data points is measured from a communus signal as given in Table 6.2,

	Ha
D	0.10
1	1.05
2	1.92
3	3.90
4	4.02
5	4.94

Table 6.2 Data for Digital-Filtering Example

A simple input averaging filter with α values of 0.25, 0.5, 0.75, and 1.0 is used to filter these values as depicted later (Figure 6.11). The filters produce a continuum of response patterns indicating that no single value of α is best. However, one can argue, based on proximity to the general pattern of the input signal, that $\alpha = 0.5$ may be reasonable. In practice, one has to fine-tune α or similar parameters of a given filter to fit the application in wind. There we, as shown inter, formal methods (based on digital signal processing) that allow the user to select the filter parameter to affect the frequency response of the filter (similar to the analogue case). The mathematical techniques underlying these tools are beyond the more of this book although their application is discussed later.



Figure 6.11 Simple averaging filter results.

6.3.4 Lob VIEW Implementation

One can implement a digital filter in LabVIEW as shown in Figure 6.12. The block diagram of this filter appears in Figure 6.13. The filter parameters are set at 0.5 and 0.5 in the lower left corner of the front panel bus can be changed if necessary. The block diagram depicts a annusoidal signal generator, as well as a noise generator on the left side. The in-place operation allows the addition of individual data elements.

The im-place element structure allows a simple operation such as addition to occur on the corresponding elements of two dynamic arrays produced by the sinusoidal and noise signal generators. This node can be found in the structures subpalette of the programming section of the functions palette as depicted in Figure 6.14.

The filter itself is implemented as a *finite impulse response* (FIR) filter node (found in the advanced FIR filtering section of the filters subpalette of the signal-processing section of the functions palette), which effectively implements a *moving average* filter type. The array of filter coefficients appears in the front panel of Figure 6.12. Note that in this case the source



Figure 6.12 Front panel of a simple digital filter.

The location of these notes in the m-pactive paintie may change depending on the version of LabVIEW [1 the harware, possible to search for a specific type of multi by some and locate it insequenties of its location.



Figure 6.13 Diagram of a simple digital filter.



Structures subpatence of the functions points.

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signal is generated internally but it is possible to do the same task using an external input signal, as, for instance, generated by a function generator.

6.3.5 Higher Order Digital Filters

While the simple filter in the previous section works reasonably well, one can build more effective filters using a combination of autoregressive terms and moving average terms, via an ARMA model, also referred to as an infinite impulse response (IIR) filter. The general aquation for such a filter is given as

 $y_{k} = -a_{1}y_{k-1} - a_{2}y_{k-2} - a_{1}y_{k-3} + \dots + b_{k}a_{k} + b_{1}a_{k-1} + b_{2}a_{k-2} + b_{3}a_{1-1} + \dots \quad (6.13)$

Note that *a*, and *b*, must be chosen properly for stable and effective performance. This is not a arivial task and requires advanced techniques that extend beyond the scope of this text. The essential idea is to place the so-called poles and zeros (the roots of the denominator and momentor of the corresponding discrete time transfer function) in reasonable locations in the complex plane. However, there are well-known design strategies that have performed well, including Butterworth, Chebyshev, and Bessel, that are programmed in LabVIEW. It is also possible to produce the filter coefficients in Matheb or a similar tool and use a similar technique as in the previous section (albeit using an UR filter node) to implement the given filter. Implementation using LabVIEW built-in functions is depicted in Figure 6.15. Filter parameters



Figure 6.15 Frant panel of Butterworth filter design.

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Block diagram of Butterworth filter design.

include the sampling frequency, which in this case is the same frequency used to generate the segnal in the first place. The cutoff frequency is also another required parameter, which is chosen to correspond to the frequency at which the noise components start to dominate the real section of the function palette) requires filter type (set to zero for a low-pass filter) as well as the two parameters mentioned earlier. Note that the unconnected terminal of the filter mode (the bigh-frequency cutoff) is not required for a low-pass or high-pass filter but is required for a handpass filter.

The response of the filter depicted in the front panel diagram in Figure 6.15 typifies the low pass filtering effect of a Batterworth filter, which indeed performs better than the simple filter we daughed series.

6.4 Condusions

This chapter manifered signal-processing techniques used commonly in conjunction with communication with data acquisition systems. As a prelide to digital signal processing via LabVIEW, we manifered analogue signal processing using operational amplifiers (op-suppl). This process is often constant to successful computer based data acquisition, as the original result may be constant at to successful computer based data acquisition, as the original to the appearance of ghost images on television screens). We further discussed digital moving average and autoregressive moving average models.

6.5 Problems

- 6.1. Implement the analogue filter design described in Figure 6.10 using a pair of LM-741 op-amps and appropriate registors and capacitors. You will need to choose a reasonable capacitor value for C, say 0.1pF, and then choose an appropriate resistor value for R2b to achieve a comer frequency of 10 Hz (effectively 60 rad/s). For this exercise, design the gain of your filter to be unity (1) by selecting $R_{10} = R_{20}$. Likewise, choose $R_{10} = R_{10}$ because you will use the first stage only to invert the signal produced by the function generator (since it will be inverted again by the second stage filter). In building the circuit, pay close attention to the color coding marked on the figure. Do not power up the board or connect power to the circuit without first ensuring that connections are made property.
- 6.2. Perform preliminary evaluation of the filter in the previous energies by generating a signal using a function generator capable of producing a sinusoidal function of varying frequency (similar to that shows in the previous chapter). You can connect the function generator output to v, input in the filter and ground v, input since it is not used in this exercise. (It is always good practice to ground unused inputs to proven the circuit from picking up and introducing noise in the actual signal.) You will need an oscilloscope to evaluate the functioning of the filter. Vary the frequency of the signal from 1 to 100 Hz and make an estimate of the filter performance (in terms of attenuation of the signal amplitude) by recording (reading off the scope) the amplitude of the signal as a function of frequency. Compare your graph with Figure 6.2. Note that the figure is drawn on a logarithmic scale. Be mindful of this fact in your comparison. Bear in mind the corner frequency of the filter, which is expected to be at 10 Hz.
- 6.3. Create the VI shown in Figure 6.17. This VI can be used to evaluate the analogue filter discussed in the previous exercises. The signal generated by the VI is filtered with the analogue filter implemented in the previous exercises. The spectrum of both unfiltered and filtered signals is shown in the respective panels of the front panel of the VI. Set the wave type to be a sine wave, the frequency to be 10 Hz, the amplitude to be between 2 and 5 V, and the noise amplitude to be 10% of the signal amplitude. Use an oscilloscope to verify that you are producing the correct signal. Note that the VI should be implemented such that the Analogue Output Channel 0 on the National instruments interface board is used to produce the generated signal. In additionexamine the spectrum of the signal given in the VI. Later you will want to filter the noise, not the signal. Having an idea of where the spectrum of the signal dominated enables one to filter the signal property.

6.4. You can use the signal generated by the VI (via Analogue Output Channel II) of Figure 6.17 with the analogue filter from the previous exercises. The output of the film should be used as Analogue input Channel 0 so you can evaluate the performance



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Figure 6.17 Front panel of analogue filter test VI.

the analogue filter using the VI. Set the noise amplitude to zero in your VI. Starting 1 Hz, adjust the frequency in steps of 2, 5, and 10, up to 1000 Hz. Determine the inquency at which the filtered wave amplitude is 1/10th the original signal amplitude. Al., review the spectrum of the signal as it appears in the respective panel of the VI. step, you will evaluate the performance of the filter as a function of moine multitude. You will first set the organi frequency at 10 Hz, and set the amplitude to be 2. Adjust the noise amplitude from 0 to 2 V. Measure the amplitude of the filtered and fill in Table 6.3. In addition, note the impact of increasing the noise amplitude on the filtered spectrum of the filtered and unfiltered signals.

.

Table 6.3 Noise Acconuction as a Function of Amplitude	
Nuise amp (V)	Phored amp (V)
0.1	
0.2	
0.5	
8.8	
1	
1.5	
2	
3	
5	

- 6.6. You can demonstrate further how the filter may be used in a real system. To do this you can use a small fan with a small weight attached to one of the blades with study tape that prevents the added weight to fly off as the fan rotates. A semiconductor-based (MEMS) accelerometer similar to that shown in Figure 6.18 may be attached to the base of the fan to record the acceleration due to an unbalanced rotor. We wish to filter out all the nome that occurs above the fan's rotational frequency. In order to do this, we must first know what the frequency is. Determine the frequency from the fan specifications, which should be available from manufacturer data sheets.
- 6.7. Create the VI for use with the accelerometer as shown in Figure 6.19. The VI must be able to read the accelerometer signal and produce filtered and unfiltered displays of this signal along with the spectrum of the signal.
- 6.8. Connect the accelerometer to the amplifier in Figure 6.9. The accelerometer, in the packaging shown in Figure 6.18, is manufactured by Analog Devices (and is connected)



Henro 6.18 MEMS accelerometer (Analog Devices).



Figure 6.19 VI for use with accelerometer.

readily with the filter). Examine the output of the filter on an oscilloscope to ensure that the signal from the accelerometer makes sense. Assuming that the accelerometer is attached to the base of the fan (in normally operating condition, i.e., without any added mass to create rotor unbalance) you should see the fan frequency on the oscilloscope. The accelerometer may have an offset that can be removed in the next step.

- 6.9. Using the VI developed earlier, produce the offset necessary to eliminate the accelerometer offset.
- 6.10. Given the frequency of the fan at its high setting, calculate the corner frequency that would be needed to filter the rotational speed of the fan. You may use the same filter that you used previously or, if the corner frequency is very different, you may change your resistances to achieve a better design. In addition, you will need to increase the gain of your amplifier to amplify the accelerometer voltage and subtract off the DC offset.
- 6.11. Examine the effects of adding an imbalance to the fan. Power down the board, disconnect the balanced fan, and connect the unbalanced fan following the more procedure.
- 6.12. Modify the filter in Figure 6.12 so that it allows a dial gauge to represent x, the filter parameter. This is a simple modification but allows you to better understand the filter structure.

- 6.13. Create a case diagram to allow multiple types of noise (uniform, etc.) to be added to the signal in Figure 6.12, Does changing the wave type seem to have any effect on the quality of the filtered output? Does the filter reproduce each wave exactly?
- 6.14. What effect does changing the frequency have on the spectrum of filtered and unfiltered signals? What happens to the frequency spectrum of the filtered signal as high frequencies?
- 6.15. What is the effect of noise amplitude? What happens when it is small? What is the result when it gets to be the same amplitude as that of the right, or larger? How did changing the noise amplitude affect the frequency spectrum? What information does this give you?
- 6.16. In using unbalanced fan vibration as the source of your measurements, compare the filtered responses at low and high speeds with unfiltered responses. For which fan speed is the filtered response cleaner? How does this relate to your cutoff frequency?
- 6.17. For the experiments discussed earlier the fan speeds were fairly close, so designing a filter that would be acceptable for both speeds is not very difficult. What are nome of the problems with trying to use the same filter design if the two speeds are dramically different? (Hint: If the speed is low, how will the noise frequencies change?)
- 6.18. What are some potential problems of using filters in real systems? (Hint: In the earlier exercises, we knew executly what we were looking for. What if we do not?)
- 6.19. Why does high-frequency noise get reduced in low-pass digital filters?
- 6.20. Would using more sample points in the filter be beneficial in eliminating high-frequency noise? What would happen if too many points are used, that is, close to the total number of data points collected?
- 6.21. What are some potential problems of using filters in real systems? (Hint: Think if you need data in real time and a higher order filter is needed.)

6.6 Appendix

6.6.1 Simple Filter Solution

We start with

$$\frac{\hat{v}_{\mu}}{\hat{v}_{i}} = \frac{1}{tt+1}.$$

Assuming sinusoidal functions of the form

$$v_i = V_i(\omega t), \text{ or } \hat{v}_i = \frac{\omega V_i}{x^2 + \omega^2}.$$

(6.14)

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We have the following pastial fraction exapansion

$$F_{o} = \frac{1}{\tau s + 1} \frac{\omega V_{i}}{s^{2} + \omega^{2}} = \frac{A}{s + 1/\tau} + \frac{B}{s + j\omega} + \frac{C}{s - j\omega}.$$
 (6.15)

oterc

$$A = \lim_{k \to -1/2} (x + 1/\tau) \hat{v}_0(x) = \frac{\omega V_i}{(-1/\tau)^2 + \omega^2} = \frac{\omega r^2 V_i}{1 + \tau^2 \omega^2}$$
(6.16)

$$B = \lim_{x \to -ijm} (x + j\omega)\hat{v}_{\sigma}(x) = \frac{\omega V_i}{(-j\tau\omega + 1)(-2j\omega)} \qquad (6.17)$$

$$C = \lim_{x \to i\infty} (x - j\omega) \hat{v}_{\sigma}(x) = \frac{\omega V_i}{(j \pi \omega + 1)(2j\omega)} \qquad (6.18)$$

Now noting that

$$v_{\sigma}(t) = Ae^{-t/\tau} + Be^{-\mu\omega} + Ce^{\mu\omega}$$
 (6.19)

and that the first term dies out with time, we look at the steady state value of $v_{\sigma}(t)$ as

$$v_{o}(t) = \frac{\omega V_{i}}{(-j\tau\omega + 1)(-2j\omega)}e^{-j\omega} + \frac{\omega V_{i}}{(j\tau\omega + 1)(2j\omega)}e^{-j\omega}$$
(6.20)

and further into

$$u_{-}(t) = \frac{(/t\omega + 1)V_{i}}{(\tau^{2}\omega^{2} + 1)(-2)}e^{-i\omega t} + \frac{(-jt\omega + 1)V_{i}}{(\tau^{2}\omega^{2} + 1)(2)}e^{-i\omega t}$$
(6.21)

and further into

$$w_0(t) = \frac{V_t}{(t^2 \omega^2 + 1)(-2j)} ((jt\omega + 1)e^{-j\omega t} - (-jt\omega + 1)e^{j\omega t})$$
(6.22)

and

$$w_0(t) = \frac{v_1}{(t^2\omega^2 + 1)(-2/)} \left(+jt\omega(e^{j\omega t} + e^{-j\omega t}) - (e^{j\omega t} - e^{-j\omega t})\right)$$
(6.23)

$$n_0(t) = \frac{V_1}{(\tau^2 \omega^2 + 1)(-2j)} (2j \cos \cos(\omega t) - 2j \sin(\omega t))$$
(6.24)

$$\mathbf{v}(t) = \frac{V_i}{\tau^2 c \tau^2 + 1} \left(-\tau \omega \cos(\omega t) + \operatorname{nin}(\omega t) \right)$$
(6.25)

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and

$$v_0(t) = V_i(-\sin(\phi)\cos(\omega t) + \cos(\phi)\sin(\omega t))$$
(6.26)

where $tao(\phi) = \tau \omega$. We thus have

$$v_0(t) = V_t \min(\alpha t - \varphi). \tag{6.27}$$

6.6.2 Matlab Solution to the Butterworth Filter Design

As you observed simple first-order filters may do well for eliminating random noise, but they do not do well at attenuating signals with a certain frequency. For this reason, there are many other digital-filtering approaches. Many revolve around designing an analogue filter and approximating it as a digital filter. This is the case for the Butterworth filter. Luckily, this design process can be automated nicely using Matlab. Matlah uses a command called butter to generate the coefficients for a filter with a certain order and cutoff frequency. A sample command is given here.



The command just given generates a third-order Butterworth filter. The first term in the command (3 in this example) is the order of the filter. By setting this term, you can control how many past data points the filter uses. The second term in the argument is the ratio of the cutoff frequency to the Nyquist frequency. The Nyquist frequency is one-half of the sampling rate, at this ratio, r, is given by

$$r = \frac{f_c}{f_c/2}$$

These frequencies are both gives in Hz, which makes r a unitless quantity. It is important to not that digital filters only filter frequencies relative to the sampling frequency. If the cutoff frequency is increased and the sampling frequency is increased by the same amount, the same is achieved. In addition, the maximum value of r is 1.0 (why do you think this is?). However, this would correspond to an unfiltered response.

Recall that the equation for the filter is given by

$$y_k = \frac{1}{a_k} \left(-a_k y_{k-1} - a_2 y_{k-2} - a_3 y_{k-3} + b_3 u_k + b_1 u_{k-1} + b_2 u_{k-2} + b_3 u_{k-3} \right).$$

The *b* vector contains the b_i coefficients. The leftmost number corresponds to b_0 . The next number corresponds to b_1 and no on. The coefficients of *a* are given by the next vector. Notice that our Butterworth fifter has an a_0 term. This isn't present is the main part of the lab. The present for this is that the term is always not to be 1, as seen by the values of *a* given endier. So, multizing that a_0 is always one allows us to simplify this expression into the following:

$$y_{k} = -a_{1}y_{k-1} - a_{2}y_{k-2} - a_{3}y_{k-3} + a_{2}u_{k} + b_{1}u_{k-1} + b_{2}u_{k-2} + b_{3}u_{k-3}$$

Here are a few additional examples of Butterworth filter designs:

For more information on this subject, no Digital Signal Processing by Proskis and Macolakas.



CHAPTER 2

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7.1 Introduction

The mode of operation of most measuring instruments is to convert the measured quantity into an electrical signal. Usually, this output quantity is in the form of voltage, although other forms of output, such as signal frequency or phase changes, are sometimes found.

We shall learn in this chapter that the magnitude of voltage signals can be measured by various electrical indicating and test instruments. These can be divided broadly into electrical

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meters (in both analogue and digital forms) and various types of oscilloscopes. As well as signal level voltages, many of these instruments can also measure higher magnitude voltages, and this is indicated where appropriate. The oscilloscope is particularly useful for interpreting instrument outputs that exist in the form of a varying phase or frequency of an electrical signal,

Electrical meters exist in both digital and analogue forms, although use of an analogue form now tends to be restricted to panel meters, where the analogue form of the output display means that abnormal conditions of monitored systems are identified more readily than is the case with the numeric form of output given by digital meters. The various forms of digital and analogue meters found commonly are presented in Sections 7.2 and 7.3.

The oscilloscope is a very versatile measuring instrument widely used for signal measurement, despite the measurement accuracy provided being inferior to that of most meters. Although existing in both analogue and digital forms, most instruments used professionally are now digital, with analogue versions being limited to inexpensive, low-specification instruments intended for use in educational establishments. Although of little use to professional users, the features of analogue instruments are covered in this chapter because students are quite likely to meet these when doing practical work associated with their course. As far as digital oscilloscopes are concerned, the basic type of instrument used is known as a digital storage oscilloscope. More recently, digital phosphor oscilloscopes have been introduced, which have a capability of detecting and recording rapid transients in voltage signals. A third type is the digital sampling oscilloscope, which is able to measure very high-frequency signals. A fourth and final type is a personal computer (PC)-based oscilloscope, which is effectively an add-on unit to a standard PC. All of these different types of oscilloscopes are discussed in Section 7.4.

7.2 Digital Meters

All types of digital meters are basically modified forms of the digital voltmeter (DVM). irrespective of the quantity that they are designed to measure. Digital meters designed to measure quantities other than voltage are, in fact, digital voltmeters that contain appropriate electrical circuits to convert current or resistance measurement signals into voltage signals. Digital multimeters are also essentially digital voltmeters that contain several conversion circuits, thus allowing the measurement of voltage, current, and resistance within one instrument.

Digital meters have been developed to satisfy a need for higher measurement accuracies and a faster speed of response to voltage changes than can be achieved with analogue instruments They are technically superior to analogue meters in almost every respect. The binary nature of the output reading from a digital instrument can be applied readily to a display that is in the form of discrete numerals. Where human operators are required to measure and record signal voltage levels, this form of ostput makes an important contribution to measurement reliability and

accuracy, as the problem of analogue meter parallax error is eliminated and the possibility of gross error through misreading the meter output is reduced greatly. The availability in many instruments of a direct output in digital form is also very useful in the rapidly expanding range of computer control applications. Quoted inaccuracy values are between ±0.005% (measuring d.c. voltages) and $\pm 2\%$. Digital meters also have very high input impedance (10 MΩ compared with 1-20 KΩ for analogue meters), which avoids the measurement system loading problem (see Chapter 3) that occurs frequently when analogue meters are used. Additional advantages of digital meters are their ability to measure signals of frequency up to I MHz and the common inclusion of features such as automatic ranging, which prevents overload and reverse polarity connection, etc.

The major part of a digital voltmeter is the circuitry that converts the analogue voltage being measured into a digital quantity. As the instrument only measures d.c. quantities in its basic mode, another necessary component within it is one that performs a.c.-d.c. conversion and thereby gives if the capacity to measure a.c. signals. After conversion, the voltage value is displayed by means of indicating tubes or a set of solid-state light-emitting diodes. Four-, five-, or even six-figure output displays are used commonly, and although the instrument itself may not be inherently more accurate than some analogue types, this form of display enables measurements to be recorded with much greater accuracy than that obtainable by reading an analogue meter scale.

Digital volumeters differ mainly in the technique used to affect the analogue-to-digital ponversion between the measured analogue voltage and the output digital reading. As a general rule, the more expensive and complicated conversion methods achieve a faster conversion speed. Some common types of DVM are discussed here.

7.2.1 Voltage to Time Conversion Digital Voltmater

This is the simplest form of DVM and is a ramp type of instrument. When an unknown voltage signal is applied to input terminals of the instrument, a negative slope ramp waveform is puterated internally and compared with the input signal. When the two are equal, a palse is generated that opens a gate, and at a later point in time a second pulse closes the gate when the magnitive ramp voltage reaches zero. The length of time between the gase opening and closing is monitored by an electronic counter, which produces a digital display according to the level of the input voltage signal. Its main drawbacks are nonlinearities in the shape of the many Braveform used and lack of noise rejection; these problems lead to a typical insocuracy of $\pm 0.05\%$. It is relatively inexpensive, however.

7.2.2 Potentiemetric Digital Voltmeter

This uses a zervo principle, in which the error between the unknown input voltage level and a returnace voltage is applied to a servo-driven potentiometer that adjusts the reference volinge mull it balances the unknown voltage. The output reading is produced by a mechanical

drum-type digital display driven by the potentiometer. This is also a relatively inexpensive form of DVM that gives excellent performance for its price.

7.2.3 Dual-Slope Integration Digital Voltmeter

This is another relatively simple form of DVM that has better noise-rejection capabilities than many other types and gives correspondingly better measurement accuracy (inaccuracy as low as $\pm 0.005\%$). Unfortunately, it is quite expensive. The unknown voltage is applied to an integrator for a fixed time, T_1 , following which a reference voltage of opposite sign is applied to the integrator, which discharges down to a zero output in an interval, T_2 , measured by a counter. The output-time relationship for the integrator is shown in Figure 7.1, from which the unknown voltage, V_{in} can be calculated geometrically from the triangle as

 $V_{i} = V_{ref}(T_{1}/T_{2}). \tag{7.1}$

7.2.4 Voltage-to-Frequency Conversion Digital Voltmeter

In this instrument, the unknown voltage signal is fed via a range switch and an amplifier into a converter circuit whose output is in the form of a train of voltage pulses at a frequency proportional to the magnitude of the input signal. The main advantage of this type of DVM is its ability to reject a.c. noise.

7.2.5 Digital Multimeter

This is an extension of the DVM. It can measure both a.c. and d.c. voltages over a number of ranges through inclusion within it of a set of switchable amplifiers and attenuators. It is used widely in circuit test applications as an alternative to the analogue multimeter and includes protection circuits that prevent damage if high voltages are applied to the wrong range.





7.3 Analogue Meters

Despite the technical superiority of digital meters, particularly in terms of their greater accuracy and much higher input impedance, analogue meters continue to be used in a significant number of applications. First, they are often preferred as indicators in system control panels. This is because deviations of controlled parameters away from the normal expected range are spotted more easily by a pointer moving against a scale in an analogue meter rather than by variations in the numeric output display of a digital meter. A typical, commercially available analogue panel meter is shown in Figure 7.2. Analogue instruments also tend to suffer less from noise and isolation problems, which favor their use in some applications. In addition, because analogue instruments are usually passive instruments that do not need a power supply, this is often very use ful in measurement applications where a suitable main power supply is not readily available.

Analogue meters are electromechanical devices that drive a pointer against a scale. They are prone to measurement errors from a number of sources that include inaccurate scale marking during manufacture, bearing friction, bent pointers, and ambient temperature variations. Retter human errors are introduced through parallax error (not reading the scale from directly above) and mistakes in interpolating between scale markings. Quoted inaccuracy values are between ± 0.1 and $\pm 3\%$. Various types of analogue meters are used as discussed here.

7.3.1 Moving Coil Meter

A moving coil meter is a very commonly used form of analogue voltmeter because of its multivity, accuracy, and linear scale, although it only responds to d.c. signals. As shown dimensionally in Figure 7.3, it consists of a rectangular coil wound round a soft iron core that is impunded in the field of a permanent magnet. The signal being measured is applied to the coil, which produces a radial magnetic field. Interaction between this induced field and the field



Eltime analogue panel meter (repreduced by permission of Eltime Controls)





Mechanism of a moving coil meter.

produced by the permanent magnet causes torque, which results in rotation of the coil. The amount of rotation of the coil is measured by attaching a pointer to it that moves past a graduated scale. The theoretical torque produced is given by

$$T = B I h w N, \tag{7.2}$$

where B is the flux density of the radial field, I is the current flowing in the coil, k is the height of the coil, w is the width of the coil, and N is the number of turns in the coil. If the iron core is cylindrical and the air gap between the coil and pole faces of the permanent magnet is uniform, then the flux density B is constant and Equation (7.2) can be rewritten as

$$\Gamma = K I, \tag{7.3}$$

that is, torque is proportional to the coil current and the instrument scale is linear.

As the basic instrument operates at low current levels of one milliamp or so, it is only suitable for measuring voltages up to around 2 volts. If there is a requirement to measure higher voltages, the measuring range of the instrument can be increased by placing a resistance in series with the coil, such that only a known proportion of the applied voltage is measured by the meter. In this situation the added resistance is known as a *shunting resistor*.

While Figure 7.3 shows the traditional moving coil instrument with a long U-shaped permanent magnet, many newer instruments employ much shorter magnets made from recently developed magnetic reaterials such as Alnico and Alcomax. These materials produce a substantially greater flux density, which, in addition to allowing the magnet to be smaller, has additional advantages in allowing reductions to be made in the size of the coil and in increasing the usahe range of deflection of the coil to about 120°. Some versions of the instrument also have either a specially shaped core or specially shaped magnet pole faces to cater for special situations where a nonlinear scale, such as a logarithmic one, is required.

7.3.2 Moving Iron Meter

As well as measuring d.c. signals, the moving iron meter can also measure a.c. signals at squencies up to 125 Hz. It is the least expensive form of meter available and, consequently, this type of meter is also used commonly for measuring voltage signals. The signal to be measured is applied to a stationary coil, and the associated field produced is often amplified by the presence of an iron structure associated with the fixed coil. The moving element in the instrument consists of an iron vane suspended within the field of the fixed coil. When the fixed coil is excited, the iron vane turns in a direction that increases the flax through it.

The majority of moving-iron instruments are either of the attraction type or of the remainson type. A few instruments belong to a third combination type. The attraction type, where the iron vane is drawn into the field of the coil as the current is increased. is shown achematically in Figure 7.4s. The alternative repulsion type is sketched in From 7.4b. For an excitation current, /, the torque produced that causes the vane to turn is given by

$$T=\frac{l^2dM}{2d\theta}.$$

where M is the mutual inductance and θ is the angular deflection. Rotation is opposed by a spring that produces a backwards torque given by

 $T_{1} = K\theta_{1}$



At equilibrium, $T = T_{p}$ and θ is therefore given by

$$\theta = \frac{l^2 dM}{2K d\theta}$$

The instrument thus has a square-law response where the deflection is proportional to the square of the signal being measured, that is, the output reading is a root-mean-squared (r.m.s.) quantity.

(7.4)

The instrument can typically measure voltages in the range of 0 to 30 volts. However, it can be modified to measure higher voltages by placing a resistance in series with it, as in the case of moving coil meters. A series resistance is particularly beneficial in a.c. signal measurements because it compensates for the effect of coil inductance by reducing the total resistance/ inductance ratio, and hence measurement accuracy is improved. A switchable series resistance is often provided within the casing of the instrument to facilitate range extension. However, when the voltage measured exceeds about 300 volts, it becomes impractical to use a series resistance within the case of the instrument because of heat-dissipation problems, and an external resistance is used intead.

7.3.3 Clamp-on Mators

These are used for measuring circuit currents and voltages in a noninvasive manner that avoids having to break the circuit being measured. The meter clamps onto a current-carrying conductor, and the output reading is obtained by transformer action. The principle of operation is illustrated in Figure 7.5, where it can be seen that the clamp-on jaws of the instrument act as a transformer core and the current-carrying conductor acts as a primary winding. Current induced in the secondary winding is rectified and applied to a moving coil meter. Although it is



Schematic drawing of a clamp-on meter

a very convenient instrument to use, the clamp-on meter has low sensitivity and the minimum current measurable is usually about 1 amp.

7.3.4 Analogue Multimeter

The analogue multimeter is now less common than its counterpart, the digital multimeter, but is still widely available. It is a multifunction instrument that can measure current and resistance, as well as d.c. and a.c. voltage signals, Bastenlly, the instrument contists of a moving coil malogue meter with a switchable bridge rectifier to allow it to measure a.c. signals, as shown in Figure 7.6. A set of rotary switches allows the selection of various series and shunt resistence, which make the instrument capable of measuring both voltage and current over a number of mages. An internal power source is also provided to allow it to measure resistances as well. While this instrument is very useful for giving an indication of voltage levels, the compromises in its design that enable it to measure so many different quantities necessarily mean that its measures is not as good as instruments that are purposely designed to measure just one quantity over a single measuring range.

7.3.5 Measuring High-Frequency Signals with Analogue Meters

One major limitation in using analogue meters for a.c. voltage measurement is that the maximum frequency measurable directly is low—2 kHz for the dynamometer voltmeter and only 100 Hz in the case of the moving iron instrument. A partial solution to this limitation is to rectify the voltage signal and then apply it to a moving coil meter, as shown in Figure 7.7. This extends the apper measurable frequency limit to 20 kHz. However, inclusion of the bridge rectifier makes the measurement system particularly sensitive to environmental temperature.



Circuitry of an analogue multimeter



Measurement of high-frequency voltage signals.

changes, and nonlinearities significantly affect measurement accuracy for voltages that are small relative to the full-scale value.

7.3.6 Calculation of Meter Outputs for Nonstandard Waveforms

The two examples given here provide an exercise in calculating the output reading from various types of analogue voltmeters. These examples also serve as a useful reminder of the mode of operation of each type of meter and the form that the output takes.

Example 7.1

Calculate the reading that would be observed on a moving coil ammeter when it is measuring the current in the circuit shown in Figure 7.8,

Solution

A moving coil meter measures mean current.

$$I = \frac{1}{2\pi} \left(\int_{0}^{\pi} \frac{5\omega t}{\pi} d\omega t + \int_{\pi}^{\pi} 5\sin(\omega t) d\omega t \right) = \frac{1}{2\pi} \left(\left[\frac{5(\omega t)^{2}}{2\pi} \right]_{0}^{\pi} + 5[-\cos(\omega t)]_{\pi}^{2\pi} \right)$$
$$= \frac{1}{2\pi} \left(\frac{5\pi^{2}}{2\pi} - 0 - 5 - 5 \right) = \frac{1}{2\pi} \left(\frac{5\pi}{2} - 10 \right) = \frac{5}{2\pi} \left(\frac{\pi}{2} - 2 \right) = -0.342 \text{ amps}$$







Example 7.2

Calculate the reading that would be observed on a moving iron ammeter when it is measuring the current in the circuit shown in Figure 7.8,

Folution

A moving iron meter measures r.m.s. current

$$\begin{split} t^{2} &= -\frac{1}{2\pi} \left(\int_{0}^{1} \frac{25(4d)^{2}}{\pi^{2}} d\omega t + \int_{0}^{10} 25 \sin^{2}(\omega t) d\omega t \right) = \frac{1}{2\pi} \left(\int_{0}^{1} \frac{25(\omega t)^{2}}{\pi^{4}} d\omega t + \int_{0}^{10} \frac{25(1 - \cos 2\omega t)}{2} d\omega t \right) \\ &= \frac{25}{2\pi} \left(\left[\frac{(\omega t)^{2}}{3\pi^{2}} \right]_{0}^{4} + \left[\frac{\omega t}{2} - \frac{\sin 2\omega t}{4} \right]_{0}^{2\eta} \right) = \frac{25}{2\pi} \left(\frac{\pi}{3} + \frac{2\pi}{2} - \frac{\pi}{2} \right) \\ &= \frac{25}{2\pi} \left(\frac{\pi}{3} + \frac{\pi}{2} \right) = \frac{25}{2} \left(\frac{1}{3} + \frac{1}{2} \right) = 10.416 \\ m_{1} t_{m} = \sqrt{(P_{m})} = 3.23 \text{ grap} \end{split}$$

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7.4 Oscilloscopes

The oscilloscope is probably the most versatile and useful instrument available for signal measurement. While oscilloscopes still exist in both analogue and digital forms, analogue models tend to be low specification, low-cost instruments produced for educational use in schools, colleges, and universities. Almost all oscilloscopes used for professional work now tend to be digital models. These can be divided into digital storage oscilloscopes, digital phosphor oscilloscopes, and digital sampling oscilloscopes.

The basic function of an oscilloacope is to draw a graph of an electrical signal. In the most common arrangement, the y axis (vertical) of the display represents the voltage of a measured signal and the x axis (horizontal) represents time. Thus, the basic output display is a graph of the variation of the magnitude of the measured voltage with time.

The oscilloscope is able to measure a very wide range of both a.c. and d.c. voltage signals and is used particularly as an item of test equipment for circuit fault finding. In addition to measuring voltage levels, it can also measure other quantities, such as the frequency and phase of a signal. It can also indicate the nature and magnitude of noise that may be corrupting the measurement signal. The most expensive models can measure signals at frequencies up to 25 GHz, while the least expensive models can only measure signals up to 10 MHz. One particularly strong merit of the oscilloscope is its high input impedance, typically 1 MQ, which means that the instrument has a negligible loading effect in most measurement situations. As a test instrument, it is often required to measure voltages whose frequency and magnitude are totally unknown. The set of rotary switches that alter its time base so easily, and the circuitry that protects it from damage when high voltages are applied to it on the wrong range, make it ideally suited for such applications. However, it is not a particularly accurate instrument and is best used where only an approximate measurement is required. In the best instruments, inaccuracy can be limited to $\pm 1\%$ of the reading, but inaccuracy can approach $\pm 5\%$ in the least expensive instruments.

The most important aspects in the specification of an oscilloscope are its bandwidth, rise time, and accuracy. Bandwidth is defined as the range of frequencies over which the oscilloscope amplifier gain is within 3 dB⁺ of its peak value, as illustrated in Figure 7.9. The -3-dB point is where the gain is 0.707 times its maximum value. In most oscilloscopes, the amplifier is direct coupled, which means that it amplifies d.c. voltages by the same factor as low-frequency a.c. ones. For such instruments, the minimum frequency measurable is zero and the bandwidth can be interpreted as the maximum frequency where the nemitivity (deflection/volt) is within 3 dB of the peak value. In all measurement situations, the oscilloscope chosen for use must be such

The docibal, constantly written dB, is used to express the ratio between two quantities. For two voltage levels, Y_1 and V_2 , the difference between the two levels is expressed in decibels as 20 $\log_{10}(V_1/V_2)$. It follows from the third 20 $\log_{10}(0.7071) = -3.48$.



that the maximum frequency to be measured is well within the bandwidth. The -3.48maxification means that an oscilloscope with a specified inaccuracy of $\pm 2\%$ and a bandwidth of 100 MHz will have an inaccuracy of $\pm 5\%$ when measuring 30-MHz signals; this inaccuracy will increase still further at higher frequencies. Thus, when applied to signal-amplitude measurement, the oscilloscope is only usable at frequencies up to about 0.3 times its specified indwidth.

Rise time is the transit time between 10 and 90% levels of the response when a step input is applied to the oscilloscope. Oscilloscopes are normally designed such that

bandwidth \times rise time = 0.35.

Thus, for a bandwidth of 100 MHz, rise time = 0.35/100,000,000 = 3.5 ns.

All ancilloscopes are relatively complicated instruments constructed from a number of subsystems, and it is necessary to consider each of these in turn in order to understand how the complete instrument functions. To achieve this, it is useful to start with an explanation of an available oscilloscope, as this was the original form in which oscilloscopes were made and many of the terms used to describe the function of oscilloscopes emanate from analogue forms.

7.4.1 Analogue Oscilloscope (Cothodo Ray Oscilloscope)

Accepte oscilloscopes were originally called cathode my oscilloscopes because a fundamental exception within them is a cathode my tube. In recent times, digital oscilloscopes have above minute replaced analogue versions in professional use. However, some very inexpensive and analogue oscilloscopes still exist that find educational uses in schools, colleges, and

universities. The low cost of basic analogue models is their only merit, as their inclusion of a cathode my tube makes them very fragile, and the technical performance of digital equivalents is greatly superior.

The cathode ray tube within an analogue oscilloscope is shown schematically in Figure 7.10, The cathode consists of a barium and strontium oxide-coated, thin, heated filament from which a stream of electrons is emitted. The stream of electrons is focused onto a well-defined spot on a fluorescent screen by an electrostatic focusing system that consists of a series of metal discs and cylinders charged at various potentials. Adjustment of this focusing mechanism is provided by a *focus* control on the front panel of an oscilloscope. An *intensity* control varies the cathode heater current and therefore the rate of emission of electrons, and thus adjusts the intensity of the display on the screen. These and other typical controls are shown in the illustration of the front panel of a simple oscilloscope given in Figure 7.11. It should be noted that the layout shown is only one example. Every model of oscilloscope has a different layout of control knobs, but the functions provided remain similar irrespective of the layout of the controls with respect to each other.

Application of potentials to two sets of deflector plates mounted at right angles to one another within the tube provide for deflection of the stream of electrons, such that the spot where the electrons are focused on the screen is moved. The two sets of deflector plates are normally known as horizontal and vertical deflection plates, according to the respective motion caused to the spot on the screen. The magnitude of any signal applied to the deflector plates can be calculated by measuring the deflection of the spot against a cross-wires graticule etched on the screen.

Channel

One channel describes the basic subsystem of an electron source, focusing system, and deflector plates. This subsystem is often duplicated one or more times within the cathode ray tube to provide a capability of displaying two or more signals at the same time on the screen.



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Figure 7.11 Controls of a simple oscilloscope.

The normon oscilloscope configuration with two channels can therefore display two separate signals simultaneously.

Implemented input

This type of input only has one input terminal plus a ground terminal per oscilloscope channel managemently, only allows signal voltages to be measured relative to ground. It is normally thed in simple oscilloscopes.

D.Smetial input

This type of input is provided on more expensive oscilloscopes. Two input terminals a pround terminal are provided for each channel, which allows the potentials at two maded points in a circuit to be compared. This type of input can also be used in terminals plus ground to measure a signal relative to ground by using just one of the input terminals plus ground.

Time bess circuit

The purpose of a time base is to apply a voltage to the horizontal deflector plates such that the horizontal position of the spot is proportional to time. This voltage, in the form of a ramp known as a sweep waveform, must be applied repetituvely, such that the motion of the spot across the screen appears as a straight line when a d.c. level is applied to the input channel, Furthermore, this time base voltage must be synchronized with the input signal in the general case of a time-varying signal, such that a stendy picture is obtained on the oscilloscope screen. The length of time taken for the spot to traverse the screen is controlled by a *time/div* switch, which sets the length of time taken by the spot to travel between two marked divisions on the screen, thereby allowing signals at a wide range of frequencies to be measured.

Each cycle of the sweep waveform is initiated by a pulse from a pulse generator. The input to the pulse generator is a siausoidal signal known as a triggering signal, with a pulse being generated every time the triggering signal crosses a preselected slope and voltage level condition. This condition is defined by *trigger level* and *trigger slope* switches. The former selects the voltage level on the trigger signal, commonly zero, at which a pulse is generated, while the latter selects whether pulsing occurs on a positive or negative going part of the triggering waveform.

Synchronization of the sweep waveform with the measured signal is achieved most easily by deriving the trigger signal from the measured signal, a procedure known as *Internal triggering*. Alternatively, *external triggering* can be applied if the frequencies of the triggering signal and measured signals are related by an integer constant such that the display is stationary. External triggering is necessary when the amplitude of the measured signal is too small to drive the pulse generator; it is also used in applications where there is a requirement to measure the phase difference between two sinusoidal signals of the same frequency. It is very convenient to use 50-Hz line voltage for external triggering when measuring signals at mains frequency; this is often given the name *line triggering*.

Vertical sansitivity control

This consists of a series of attenuators and preamplifiers at the input to the oscilloscope. These condition the measured signal to the optimum magnitude for input to the main amplifier and vertical deflection plates, thus enabling the instrument to measure a very wide range of different signal magnitudes. Selection of the appropriate input amplifier/attenuator is made by setting a *volts/div* control associated with each oscilloscope channel. This defines the magnitude of the input signal that will cause a deflection of one division on the screen.

Display position control

This allows the position at which a signal is displayed on the access to be controlled in two ways. The horizontal position is adjusted by a *horizontal position* knob on the oscillowed front panel, and similarly a *vertical position* knob controls the vertical position. These control adjust the position of the display by biasing the measured signal with d.c. voltage levels.

7.4.2 Digital Storage Oscillascopes

Digital storage oscilloscopes are the most basic form of digital oscilloscopes but even these usually have the ability to perform extensive waveform processing and provide permanent storage of measured signals. When first created, a digital storage oscilloscope consisted of a conventional analogue cathode ray oscilloscope with the added facility that the measured analogue signal could be converted to digital format and stored in computer memory within the instrument. These stored data could then be reconverted to analogue form at the frequency pecessary to refresh the analogue display on the screen, producing a nonfading display of the signal on the screen.

While examples of such early digital oscilloscopes might still be found in some workplaces, modern digital storage oscilloscopes no longer use cathode ray tubes and are entirely digital in meastruction and operation. The front panel of any digital oscilloscope has a similar basic myout to that shown for an analogue oscilloscope in Figure 7.11, except that the controls for "focusing" and "intensity" are not needed in a digital instrument. The block diagram in Figure 7.12 shows typical components used in the digital storage oscilloscope. A typical memorical instrument was also shown earlier in Figure 5.1. The first component (as in an majogue macilloscope) is an amplifier/attenuator unit that allows adjustment of the magnitude of the input voltage signal to an appropriate level. This is followed by an analogue-to-digital converter that samples the input signal at discrete points in time. The sampled signal values are stored in the acquisition memory component before passing into a microprocessor. This carries out signal processing functions, manages the front panel control settings, and prepares the output display. Following this, the output signal is stored in a display memory module before buing output to the display itself. This consists of either a monochrome or a multicolor liquid crystal display (see Chapter 8). The signal displayed is actually a sequence of individual dots rather than a continuous line as displayed by an analogue oscilloscope. However, as the domany of dots increases, the display becomes closer and closer to a continuous line. The density of the



Components of a digital storage oscilloscope.

dots is entirely dependent on the sampling rate at which the analogue signal is digitized and the rate at which the memory contents are read to reconstruct the original signal. As the speed of sampling and signal processing is a function of instrument cost, more expensive instruments give better performance in terms of dot density and the accuracy with which the analogue signal is recorded and represented. Nevertheless, the cost of computing power is now sufficiently low to mean that all but the least expensive instruments now have a display that looks very much like a continuous trace.

In addition to their ability to display the magnitude of voltage signals and other parameters, such as signal phase and frequency, most digital oscilloscopes can also carry out analysis of the measured waveform and compute signal parameters such as maximum and minimum signal levels, peak-peak values, meas values, r.m.s. values, rise time, and fall time. These additional functions are controlled by extra knobs and push buttons on the front panel. They are also ideally suited to capturing transient signals when set to single-sweep mode. This avoids the problem of the very careful synchronization that is necessary to capture such signals on an analogue oscilloscope. In addition, digital oscilloscopes often have facilities to output analogue signals to devices such as chart recorders and output digital signals in a form compatible with standard interfaces such as IEEE488 and RS232.

The principal limitation of a digital storage oscilloscope is that the only signal information captured is the status of the signal at each sampling instant. Thereafter, no new signal information is captured during the time that the previous sample is being processed. This means that any signal changes occurring between sampling instants, such as fast transients, are not detected. This problem is overcome in the digital phosphor oscilloscope.

7.4.3 Digital Phespher Oscillescope

This newer type of oscilloscope, first introduced in 1998, uses a parallel-processing architecturinstead of the serial-processing architecture found in digital storage oscilloscopes. The component of the instrument are shown schematically in Figure 7.13. The amplifier/attenuator and analogue to-digital converter are the same as in a digital storage oscilloscope. However, the signal processing mechanism is substantially different. Output from the analogue-to-digital converter passes into a digital phosphor memory unit, which is, is fact, entirely electronic and not composed of chemical phosphor as its name might imply. Thereafter, data follow two parallel paths. First, a microprocessor processes data acquired at each sampling instant according to the settings on the control panel and sends the processed signal to the instrument display unit. In addition to this snapshot of the input signal is nont directly to the display unit at a rate of 30 images per This enhanced processing capability enables the instrument to have a higher waveform capability rate and to detect very fast signal transients missed by digital storage oscilloscopes.

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Components of a digital phosphor oscilloscope.

7.4.4 Digital Sampling Oscilloscope

The digital sampling oscilloscope has a bandwidth of up to 25 GHz, which is about 10 times better than that achieved by other types of oscilloscopes. This increased bandwidth is achieved by reversing the positions of the analogue-to-digital converter and the amplifier, as shown in the block diagram in Figure 7.14. This reversal means that the sampled signal applied to the implifier has a much lower frequency than the original signal, allowing use of a low bandwidth amplifier. However, the fact that the input signal is applied directly to the analogue-to-digital converter without any scaling means that the instrument can only be used to measure signals whom peak magnitude is within a relatively small range of typically 1 volt peak-peak. In contrast, both digital storage and digital phosphor oscilloscopes can typically deal with inputs up to 500 volts.



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7.4.5 Personal Computer-Based Oscilloscope

A PC-based oscilloscope consists of a hardware unit that connects to a standard PC via either a USB or a parallel port. The hardware unit provides signal scaling, analogue-todigital conversion, and buffer memory functions found in a conventional oscilloscope. More expensive PC-based oscilloscopes also provide some high-speed digital signal processing functions within the hardware unit. The host PC itself provides the control interface and display facilities.

The primary advantage of a PC-based oscilloscope over other types is one of cost; the cost saving is achieved because use of the PC obviates the need for a display unit and front control panel found is other forms of oscilloscopes. The larger size of a PC display compared with a conventional oscilloscope often makes the output display easier to read. A further advantage is one of portability, as a laptop plus add-on hardware unit is usually smaller and lighter than a conventional oscilloscope. PC-based oscilloscopes also facilitate the transfer of output data into standard PC software such as spreadsheets and word processors.

Although PC-based oscilloscopes have a number of advantages over convernional oscilloscopes, they also have disadvantages. First, electronagnetic noise originating in PC circuits requires the hardware unit to be well shielded in order to avoid corruption of the measured signal. Second, signal sampling rates can be limited by the mode of connection of the hardware unit into the PC.

7.5 Summary

This chapter looked at the various ways of measuring electrical signals that form the output of most types of measuring instruments. We noted that these signals were usually in the form of varying voltages, although a few instruments have an output where either the phase or the frequency of an electrical signal changes. We observed that varying voltages could be measured either by electrical meters or by one of several forms of oscilloscopes. We also learned that the latter are also able to interpret frequency and phase changes in signals.

Our discussion started with electrical meters, which we found now mainly existed in digital form, but we noted that analogue forms also exist, which are mainly used as meters in control panels. We looked first of all at the various forms of digital meters and followed this with a presentation on the types of analogue meters still in use.

Our discussion on oscilloscopes also revealed that both analogue and digital forms exist, he we observed that analogue instruments are now predominantly limited to less expensive versions used in education markets. However, because the students at which this book i aimed are quite likely to meet analogue oscilloscopes for practical work during their courwe started off by looking at the features of such instruments. We then went on to look at the four alternative forms of digital oscilloscope that form the basis for almost all oscilloscopes used professionally. We learned that the basic form is known as a digital storage oscilloscope that even this is superior in most respects to an analogue oscilloscope. Where better performance is needed, particularly if the observed signal has fast transients, we saw that a type known as a digital phosphor oscilloscope is used. A third kind, known as a digital pampling oscilloscope, is designed especially for measuring very high-frequency signals. However, we noted that this could also measure voltage signals that were up to 1 volt peak to offering oscilloscope facilities at a lower cost than other forms of oscilloscopes, we learned that these had asveral other advantages but also some disadvantages.

7.6 Problems

- 7.1. Summarize the advantages of digital meters over their analogue counterparts.
- 7.2. Explain the four main alternative mechanisms used for affecting analogue to digital conversion is a digital voltmeter.
- 7.3. What sort of applications are analogue meters still commonly found in?
- 7.4. Explain the mode of operation of a moving coil meter.
- 7.5. Explain the mode of operation of a moving iron meter.
- 7.6. How does an oscilloscope work?
- 7.7. What are the main differences between analogue and digital oscilloscopes?
- 7.8. Explain the following terms: (a) bandwidth and (b) rise time. In designing meilloscopes, what relationship is sort between bandwidth and rise time?
- 7.9. Explain the following terms in relation to an oscilloscope: (a) channel, (b) singleended input, (c) differential input, (d) time base, (e) vertical nonsitivity, and (f) display position control.
- 7.10. Sketch a block diagram showing the main components in a digital storage oscilloscope and explain the mode of operation of the instrument.
- 7.11. Draw a block diagram showing the main components is a digital phosphor oscilloscope. What advantages does a digital phosphor oscilloscope have over a digital storage one?
- ALL Illustrate the main components is a digital sampling oscilloscope by sketching a block diagram of them. What performance advantages does a digital sampling oscilloscope have over a digital storage one?
- 7.1.1. What is a PC-based oscilloscope? Discuss its advantages and disadvantages compared with a digital oscilloscope.
- 7.14 What are the main differences among a digital storage oscilloscope, a digital phosphor Decilloscope, and a digital sampling oscilloscope? How do these differences affect feels performance and typical usage?


CHAPTER 8

Display, Recording, and Presentation of Measurement Data

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8.1 Introduction

Earlier chapters in this book have been essentially concerned with describing ways of producing the pairty, error-free data at the output of a measurement system. Having gotten that data, next consideration is how to present it in a form where it can be readily used and analyzed. This chapter therefore starts by covering the techniques available to either display measurement

Discourse line, All cashing Theory and Application

data for current use or record it for future use. Following this, standards of good practice for presenting data in either graphical or tabular form are covered, using either paper or a computer monitor screen as the display medium. This leads to a discussion of mathematical regression techniques for fitting best lines through data points on a graph. Confidence tests to assess the correctness of the line fitted are also described. Finally, correlation tests are described that determine the degree of association between two sets of data when both are subject to random fluctuations.

8.2 Display of Measurement Signals

Measurement signals in the form of a varying electrical voltage can be diaplayed either by an oscilloscope or by any of the electrical meters described earlier in Chapter 7. However, if signals are converted to digital form, other display options apart from meters become possible, such as electronic output displays or use of a computer monitor.

8.2.1 Electronic Output Displays

Electronic displays enable a parameter value to be read immediately, thus allowing for any necessary response to be made immediately. The main requirement for displays is that they should be clear and unambiguous. Two common types of character formats used in displays, seven-segment and 7×5 dot matrix, are shown in Figure 8.1. Both types of displays have the advantage of being able to display alphabetic as well as numeric information, although the seven-segment format can only display a limited 9-letter subset of the full 26-letter alphabet. This allows added meaning to be given to the number displayed by including a word or letter code. It also allows a single display unit to send information about several parameter values, cycling through each in turn and including alphabetic information to indicate the nature of the variable currently displayed.

Electronic output units usually consist of a number of side-by-side cells, where each cell displays one character. Generally, these accept either serial or parallel digital input signals, and



Character formats used in electronic displays: (a) seven segment and (b) 7 x 5 dot matrix

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the input format can be either bisary-coded decimal or ACSII. Technologies used for the indual elements in the display are either light-emitting diodes or liquid-crystal elements.

8.2.2 Computer Monitor Displays

Now that computers are part of the furniture in most homes, the ability of computers to display information is widely understood and appreciated. Computers are now both inexpensive and stably reliable and provide an excellent mechanism for both displaying and storing information. As well as alphanumene displays of industrial plant variable and status data, for which the plane exertion can vary the size of font used to display the information at will, it is also relatively easy to display other information, such as plant layout diagrams and process flow layouts. This allow a not only the value of parameters that go outside control limits to be displayed, but also their frontion on a schematic map of the plant. Graphical displays of the behavior of a measured verable are also possible. However, this poses difficulty when there is a requirement to display the variable's behavior over a long period of time, as the length of the time axis is constrained by the size of the monitor's screen. To overcome this, the display resolution has to decreme as the time period of the display increases.

Tom h acreens have the ability to display the same sort of information as a conventional computer monitor, but also provide a command-input facility in which the operator simply has to touch the acreen at points where images of keys or boxes are displayed. A full "qwerty" keyboard is often provided as part of the display. The sensing elements behind the screen are protected by glass and continue to function even if the glass gets scratched. Touch screens are usually totally sealed, thus providing intrinsically safe operation in hazardous environments.

8.3 Recording of Measurement Data

As well as displaying the current values of measured parameters, there is often a need to make continuous recordings of measurements for later analysis. Such records are particularly useful when fours develop in systems, as analysis of the changes in measured parameters in the time before the fault is discovered can often quickly indicate the reason for the fault. Options in monding data include chart recorders, digital oscilloscopes, digital data recorders, and land copy devices such as inkjet and laser printers. The various types of recorders used see discussed here.

2.3.1 Chert Recorders

Chart monders have particular advantages in providing a non-corruptible record that has the and and and "viewability." This means that all but paperless forms of chart recorders setisfy remaining the many industries that require variables to be monitored and recorded with hard-copy output, ISO VIXX) quality assurance procedures and ISO 14000

.

environmental protection systems set similar requirements, and special regulations in the defense industry go even further by requiring hard-copy output to be kept for 10 years. Hence, while many people have been predicting the demise of chart recorders, the reality of the situation is that they are likely to be needed in many industries for many years to come.

Originally, all chart recorders were electromechanical in operation and worked on the same principle as a galvanometric moving coil meter (see analogue meters in Chapter 7) except that the moving coil to which the measured signal was applied carried a pen, as shown in Figure 8.2, rather than carrying a pointer moving against a scale as it would do in a meter. The pen drew an ink trace on a strip of ruled chart paper that was moved past the pen at constant speed by an electrical motor. The resultant trace on chart paper showed variations with time in the magnitude of the measured signal. Even early recorders commonly had two or more peas of different colory so that several measured parameters could be recorded simultaneously.

The first improvement to this basic recording arrangement was to replace the galvanometric mechanism with a servo system, as shown in Figure 8.3, in which the pen is driven by a servomotor, and a seasor on the pen feeds back a signal proportional to pen position. In this form, the instrument is known as a *potentiometric recorder*. The servo system reduces the typical inaccuracy of the recorded signal to $\pm 0.1\%$, compared to $\pm 2\%$ in a galvanometric mechanism recorder. Typically, the measurement resolution is around 0.2% of the full-scale reading. Originally, the servo motor was a standard d.c. motor, but brushless servo motors are now invariably used to avoid the commutator problems that occur with d.c. motors. The position signal is measured by a potentiometer in less expensive models, but more expensive models achieve better performance and reliability using a noncontacting ultrasonic sensor to provide feedback on pen position. The difference between the pen position and





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Servo system of a potentiometric chart recorder.

the measured signal is applied as an error signal that drives the motor. One consequence of this also non-echanical balancing mechanism is that the instrument has a slow response time, in the range of 0.2–2.0 seconds, which means that electromechanical potentiometric recorders are only matable for measuring d.c. and slowly time-varying signals.

All current potentiometric chart recorders contain a microprocessor controller, where the functions vary according to the particular chart recorder. Common functions are exections of range and chart speed, along with specification of alarm modes and levels to detect when measured variables go outside acceptable limits. Basic recorders can record up to three different signals using three different colored pens. However, multipoint recorders can have 24 or more inputs and plot six or more different colored traces simultaneously. As an internative to pens, which can run out of ink at inconvenient times, recorders using a heated stylus recording signals on heat-sensitive paper are available. Another variation is the circular chart recorder, in which the chart paper is circular in shape and is rotated rather than moving translationally. Finally, paperless forms of recorder exist where the mutput display is generated entirely electronically. These various forms are discussed in more detail later.

Pen strip chart recorder

is pen strip chart recorder refers to the basic form of the electromechanical potentiometric that recorder mantioned earlier. It is also called a *hybrid chart recorder* by some manufacturers. The wood "hybrid" was used originally to differentiate chart recorders that had a microprocessor over them these that did not. However, because all chart recorders now contain a microtracence, the term hybrid has become superfluous.

to three recorders typically have up to three inputs and up to three pens in different colors, the second up to three different signals to be recorded. A typical commercially available ended in access in Figure 6.4. Chart paper comes in either roll or fan-fold form. The drive mechanism



Figure 8.4

Honeywell DPR100 strip chart recorder (reproduced by permission of Honeywell International, Inc.)

can be adjusted to move the chart paper at different speeds. The fastest speed is typically 6000 mm/hour and the slowest is typically 1 mm/hour.

As well as recording signals as a continuous trace, many models also allow for the printing of alphanumeric data on the chart to record date, time, and other process information. Some models also have a digital numeric display to provide information on the current values of recorded variables.

Multipoint strip chart recorder

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A multipoint strip chart recorder is a modification of the pen strip chart recorder that the dot matrix print head striking against an ink ribbon instead of pens. A typical model might allow up to 24 different signal inputs to be recorded simultaneously using a six-color ink ribbon. Certain models of such recorders also have the same enhancements as pen strip chart recorders in terms of printing alphanumeric information on the chart and providing a digital numeric output display.

Heated styles chart recorder

A heated-stylus chart recorder is another variant that records the input signal by apply a heated stylus to heat-sensitive chart paper. The main purpose of this alignmative prime mechanism is to avoid the problem experienced in other forms of paper-based chart of pen cartridges or printer ribbons running out of ink at inconvenient times.

Circuler chert recorder

A circular chart recorder consists of a servo-driven pen assembly that records the measured signal on a rotating circular paper chart, as shown in Figure 8.5. The rotational speed of the chart can be typically adjusted between one revolution in 1 hour to one revolution in 31 days. Recorded charts are replaced and stored after each revolution, which means replacement intervals that vary between hourly and mosthly according to the chart speed. The major advantage of a circular chart recorder over other forms is compactness. Some models have up to four different colored pen assemblies, allowing up to four different parameters to be recorded figuration of the recor

Paperless chart recorder

A paperless chart recorder, sometimes alternatively called a virtual chart recorder or a digital chart recorder, displays the time history of measured signals electronically using a color-matrix liquid crystal display. This avoids the chore of periodically replacing chart paper and iak cutridges associated with other forms of chart recorders. Reliability is also enhanced compared with alectronechanical recorders. As well as displaying the most recent time history of intenued signals on its screen, the instrument also stores a much larger past history. This stored data can be recalled in batches and redisplayed on the screen as required. The only downside compared with other forms of chart recorders is this limitation of only displaying one acreen fall of information at a time. Of course, conventional recorders allow the whole past history of signals to be viewed at the same time on hard-copy, paper recordings. Otherwise, specifications are very similar to other forms of chart recorders, with vertical motion of the screen display



varying between 1 and 6000 mm/hour, typical inaccuracy less than $\pm 0.1\%$, and capability of recording multiple signals simultaneously in different colors.

Videographic recorder

A videographic recorder provides exactly the same facilities as a paperless chart recorder but has additional display modes, such as bar graphs (histograms) and digital numbers. However, it should be noted that the distinction is becoming blurred between the various forms of paperless recorders described earlier and videographic recorders as manufacturers enhance the facilities of their instruments. For historical reasons, many manufacturers retain the names that they have traditionally used for their recording instruments but there is now much overlap between their respective capabilities as the functions provided are extended.

8.3.2 Ink-Jet and Lasor Printers

Standard computer output devices in the form of ink-jet and laser printers are now widely used as an alternative means of storing measurement system output in paper form. Because a computer is a routine part of many data acquisition and processing operations, it often makes sense to output data in a suitable form to a computer printer rather than a chart recorder. This saves the cost of a separate recorder and is facilitated by the ready availability of software that can output measurement data in a graphical format.

8.3.3 Other Recording Instruments

Many of the devices mentioned in Chapters 5 and 7 have facilities for storing measurement data digitally. These include data logging acquisition devices and digital storage oscilloscopes. These data can then be converted into hard-copy form as required by transferring it to either a chart recorder or a computer and printer.

8.3.4 Digital Data Recorders

Digital data recorders, also known as *data loggers*, have already been introduced in Chapter 5 in the context of data acquisition. They provide a further alternative way of recording measurement data in a digital format. Data so recorded can then be transferred at a future time to a computer for further analysis, to any of the forms of measurement displadevices discussed in Section 8.2, or to one of the hard-copy output devices described as Section 8.3.

Features contained within a data recorder/data logger obvioualy vary according to the particul manufacturer/model under discussion. However, most recorders have facilities to handle measurements in the form of both analogue and digital signals. Common analogue input allowed include d.c. voltages, d.c. currents, a.c. voltages, and a.c. currents. Digital input

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usually be either in the form of data from digital measuring instruments or discrete data representing events such as switch closures or relay operations. Some models also provide alarm facilities to alert operators to abnormal conditions during data recording operations.

Many data recorders provide special input facilities optimized for particular kinds of measurement sensors, such as accelerometers, thermocouples, thermistors, resistance thermometers, strain gauges (including strain gauge bridges), linear variable differential transformers, and rotational differential transformers. Some instruments also have special facilities for dealing with inputs from less common devices such as encoders, counters, timers, achometers, and clocks. A few recorders also incorporate integral sensors when they are designed to measure a particular type of physical variable.

The quality of data recorded by a digital recorder is a function of the cost of the instrument. Paying more usually means getting more memory to provide a greater data storage capacity, granter meaolution in the analogue-to-digital converter to give better recording accuracy, and faster data processing to allow greater data sampling frequency.

8.4 Presentation of Data

The two formats available for presenting data on paper are tabular and graphical, and the relative merits of these are compared later. In some circumstances, it is clearly best to use only one or the other of these two alternatives alone. However, in many data collection exercises, part of the measurements and calculations are expressed in tabular form and part graphically, making best use of the merits of each technique. Very similar arguments apply to the relative merits of graphical and tabular presentations if a computer screen is used for presentation instead of paper.

8.4.1 Tabular Data Presentation

A tabular presentation allows data values to be recorded in a precise way that exactly maintains a accuracy to which the data values were measured. In other words, the data values are written down exactly as measured. In addition to recording raw data values as measured, tables also contain further values calculated from raw data. An example of a tabular data presentation is given in Table 8.1. This records results of an experiment to determine the strain induced is a bar of material subjected to a range of streams, Data were obtained by applying a forces to the end of the bar and using an extension tree measurements and are interested in Table 8.1. The final row, which is of crucial importance in any tabular tabular tabular is the estimate of possible error in each calculated result.

		Extensioneter		
	Force Applied (KN)	Reading (Divisions)	Strees (N/m ³)	Strain
	0	0	0	0
	2	4.0	15.5	19.8×10^{-1}
	4	5.8	31.0	28.6 × 10 ⁻¹
	6	7.4	46.5	36.6 × 10 ⁻¹
	8	9.0	62.0	44.4×10^{-1}
	10	10.6	77.5	52.4 × 10 ⁻¹
	12	12.2	93.0	60.2 × 10 ⁻¹
	14	13.7	108.5	67.6 × 10 ⁻³
Possible error in				
measurements (%)	±0.2	±0.2	±1.5	±1.0

Table 8.1 Table of Manaured Applied Forces and Extensioneter Readings and Calculations of Stress and Strain

A table of measurements and calculations should conform to several rules as illustrated in Table 8.1;

- The table should have a title that explains what data are being presented within the table.
- Each column of figures in the table should refer to the measurements or calculations associated with one quantity only.
- Each column of figures should be headed by a title that identifies the data values contained in the column.
- Units in which quantities in each column are measured should be stated at the top of the column.
- All headings and columns should be separated by bold horizontal (and sometimes vertical) lines.
- Errors associated with each data value quoted in the table should be given. The form shown in Table 8.1 is a suitable way to do this when the error level is the same for all data values in a particular columa. However, if error levels vary, then it is preferable to write the error boundaries alongside each entry in the table.

8.4.2 Graphical Presentation of Data

Presentation of data is graphical form involves some compromise in the accuracy to which data are recorded, as the exact values of measurements are lost. However, graphical presentation has important advantages over tabular presentation.

- Graphs provide a pictorial representation of results that is comprehended more readily and a set of tabular results.
- Graphs are particularly useful for expressing the quantitative significance of result and showing whether a linear relationship exists between two variables. Figure 6 dates a



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Figure 8.6 Sample graphical presentation of data: graph of stress against strain.

proph draws from the stress and strain values given in Table 8.1. Construction of the proph involves first of all marking the points corresponding to the stress and strain values. The next step is to draw some liss through these data points that best represents the rolationship between the two variables. This line will normally be either a straight one or a smooth curve. Data points will not usually lie exactly on this line but instead will lie on either side of it. The magnitude of the excursions of the data points from the line drawn will depend on the magnitude of the random measurement errors associated with data. Compts can sometimes show up on a data point that is clearly outside the straight fine or curve that neems to fit the rest of the data points. Such a data point is probably due either to a human mistake in reading an instrument or to a momentary malfunction in the measuring instrument itself. If the graph shows such a data point where a human mistake or minimum malfunction is suspected, the proper course of action is to repeat that particular implication is descard the original data point of the mistake or malfunction is measured.

the tables, the proper representation of data in graphical form has to conform to certain rules:

The stript should have a title or caption that explains what data are being presented in

the same of the graph should be labeled to express clearly what variable is associated with a start axis and to define the units in which the variables are expressed.

- The number of points marked along each axis should be kept reasonably small—about five divisions is often a suitable number.
- No attempt should be made to draw the graph outside the boundaries corresponding to the maximum and minimum data values measured, that is, in Figure 8.6, the graph stops at a point corresponding to the highest measured stress value of 108.5.

Fitting curves to data points on a graph

The procedure of drawing a straight line or smooth curve as appropriate that passes close to all data points on a graph, rather than joining data points by a jagged line that passes through each data point, is justified on account of the random errors known to affect measurements. Any line between data points is mathematically acceptable as a graphical representation of data if the maximum deviation of any data point from the line is within the boundaries of the identified level of possible measurement errors. However, within the range of possible lines that could be drawn, only one will be the optimum one. This optimum line is where the sum of negative errors in data points on one side of the line is balanced by the sum of positive errors in data points on the other side of the line. The nature of data points is often such that a perfectly acceptable approximation to the optimum can be obtained by drawing a line through the data points by eye. In other cases, however, it is necessary to fit a line mathematically, using regression techniques.

Regression techniques

Regression techniques consist of finding a mathematical relationship between measurements of two variables, y and x, such that the value of variable y can be predicted from a measurement of the other variable, x. However, regression techniques should not be regarded as a magin formula that can fit a good relationship to measurement data in all circumstances, as the characteristics of data must satisfy certain conditions. In determining the suitability of measurement data for the application of regression techniques, it is recommended practical to draw an approximate graph of the measured data points, as this is often the best means of detecting aspects of data that make it unsuitable for regression madysis. Drawing a graph of data will indicate, for example, whether any data points appear to be erroneous. This may indicate the human mistakes or instrument malfunctions have affected the erroneous data points, and a assumed that any such data points will be checked for correctness.

Regression techniques cannot be applied successfully if the deviation of any particular data point from the line to be fitted is greater than the maximum possible error exclusion for the measured variable (i.e., the predicted sum of all systematic and random The nature of some measurement data sets is such that this criterion cannot be and any attempt to apply regression techniques is doomed to failure. In that event, valid course of action is to express the measurements is tabular form. This can use to used as an x-y look-up table, from which values of the variable y corresponding to particular values of x can be read off. In many cases, this problem of large errors a

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data points only becomes apparent during the process of attempting to fit a relationship by regression.

A further check that must be made before attempting to fit a line or curve to measurements of two variables, a and y, is to examine data and look for any evidence that both variables are two variables, a and y, is to examine data and look for any evidence that both variables are to random errors. It is a clear condition for the validity of regression techniques that only one of the measured variables is subject to random errors, with no error in the other variable. If madom errors do exist in both measured variables, regression techniques cannot be applied and recourse must be made instead to correlation analysis (covered later in this chapter). Simple examples of a situation where both variables in a measurement data set are subject to rendom errors are measurements of human height and weight, and no attempt should be made to fit a relationship between them by regression.

Having determined that the technique is valid, the regression procedure is simplest if a straight-line relationship exists between the variables, which allows a relationship of the form y = a + bx to be estimated by linear least-squares regression. Unfortunately, in many cases, a straight-line relationship between points does not exist, which is shown readily by plotting raw data points on a graph. However, knowledge of physical laws governing data can often taggest a suitable alternative form of relationship between the two sets of variable measurements, such as a quadratic relationship or a higher order polynomial relationship. Also, in some cases, the measured variables can be transformed into a form where a linear relationship exists. For example, suppose that two variables, y and x, are related according to y = ax'. A linear relationship from this can be derived, using a logarithmic transformation, as $\log(y) = \log(a) + c\log(x)$.

Thus, if a graph is constructed of $\log(y)$ plotted against $\log(x)$, the parameters of a straight-line relationship can be estimated by linear least-squares regression.

All quadratic and higher order relationships relating one variable, y, to another variable, s, can be represented by a power series of the form:

$y = a_0 + a_1 x + a_2 x^2 + \dots + a_n x^n$

Entremain of the parameters $a_0 \dots a_p$ is very difficult if p has a large value. Fortunately, a interconship where p only has a small value can be fitted to most data sets. Quadratic lease the regression is used to estimate parameters where p has a value of two; for larger values of p, retrinomial limit-squares regression is used for parameter estimation.

Where the appropriate form of relationship between variables is measurement data sets is not interesting the from visual inspection or from consideration of physical laws, a method measurement visual and error one has to be applied. This consists of estimating the first data sufficiently stokely higher order relationships between r and s until a curve is found that first data sufficiently closely. What level of closeness is acceptable is considered later in the on confidence tests.

Linear least-squares regression

If a linear relationship between y and x exists for a set of a measurements, $y_1 \dots y_n$, $x_1 \dots x_n$, then this relationship can be expressed as y = a + bx, where coefficients a and b are constants. The purpose of least-squares regression is to select optimum values for a and b such that the line gives the best fit to the measurement data.

The deviation of each point (x_i, y_i) from the line can be expressed as d_i , where $d_i = y_i - (a + bx_i)$.

The best-fit line is obtained when the sum of squared deviations. S_i is a minimum, that is, when

$$S = \sum_{i=1}^{n} (d_i^2) = \sum_{i=1}^{n} (y_i - a - bx_i)^2$$

is a minimum.

The minimum can be found by setting partial derivatives $\partial S/\partial a$ and $\partial S/\partial b$ to zero and solving the resulting two simultaneous (normal) equations:

$$\partial S/\partial a = \sum 2(y_i - a - bx_i)(-1) = 0$$
 (8.1)

$$\partial S/\partial h = \sum 2(y_i - a - bx_i)(-x_i) = 0 \qquad (8.2)$$

Values of the coefficients a and b at the minimum point can be represented by \ddot{a} and \ddot{b}_{a} , which are known as the least-squares estimates of a and b. These can be calculated as follows.

From Equation (8.1),

$$\sum y_i = \sum d + b \sum x_i = n\bar{a} + b \sum x_i$$

and thus,

$$= \frac{\sum y_i - \hat{b} \sum x_i}{n}.$$
 (8.3)

From Equation (8.2),

$$\sum_{i}(x_iy_i) = \hat{a}\sum_{i}x_i + b\sum_{i}x_i^2.$$

Now substitute for a in Equation (8.4) using Equation (8.3);

$$\sum_{i} (x_i \sigma_i) = \frac{(\sum y_i - b \sum x_i)}{n} \sum_{i} x_i + b \sum x_i^2.$$

Collecting terms in b.

$$b\left[\sum x_i^2 - \frac{(\sum x_i)^2}{n}\right] = \sum (x_i y_i) - \frac{\sum x_i \sum y_i}{n}.$$

Rearranging gives

$$b\left[\sum x_i^2 - n\left\{\left(\sum x_i/n\right)\right\}^2\right] = \sum (x_iy_i) - n\sum (x_i/n)\sum (y_i/n),$$

which can be expressed as

$$b\left[\sum_{i}x_{i}^{2}-nx_{m}^{2}\right]=\sum_{i}(x_{i}y_{i})-nx_{m}y_{m}.$$

where x_m and y_m are the mean values of x and y. Thus,

$$\hat{b} = \frac{\sum (x_{ij}) - nx_{m}y_{m}}{\sum x_{i}^{2} - nx_{m}^{2}}.$$
(8.5)

And, from Equation (8.3):

$$\dot{a} = y_m - bx_m. \tag{8.6}$$

Example 8.1

In an apperiment to determine the characteristics of a displacement sensor with a voltage output, the following output voltage values were recorded when a set of standard displacements was measured:

t (cm)	1.0	2.0	3.0	4.0	5.0	6.0	7.0	8.0	90	10.0
Versign	2.1	4.3	6.2	8.5	10.7	12.6	14.5	16.3	18.3	21.2

The margine line to this set of data using least-squares regression and estimate the margine margine when a displacement of 4.5 cm is measured.

W Solution

Let y represent the output voltage and a represent the displacement. Then a suitable straight line is given by y = a + bx. We can now proceed to calculate estimates for the values of and b using Equations (8.5) and (8.6). The first step is to calculate the mann values of and y. These are found to be $x_m = 5.5$ and $y_m = 11.47$. Next, we need to calculate x_p and x_p^2 for each pair of data values:

RI	yi	#491	A.2
1.0	2.1	2.1	1
2.0	4.3	8.6	4
3.0	6.2	18.6	9
1	1	1	
1	1	1	
10.0	21.2	212.0	100

Now calculate the values needed from this table -n = 10; $\sum(x_iy_i) = 801.0$; $\sum(x_i^2) = 385$ -and enter these values into Equations (8.5) and (8.6).

$$\dot{b} = \frac{801.0 - (10 \times 5.5 \times 11.47)}{385 - (10 \times 5.5^2)} = 2.067; \dot{a} = 11.47 - (2.067 \times 5.5) = 0.1033;$$

that is, y = 0.1033 + 2.067x.

Hence, for x = 4.5, $y = 0.1033 + (2.067 \times 4.5) = 9.40$ volts. Note that in this solution we have only specified the answer to an accuracy of three figures, which is the same accuracy as the measurements. Any greater number of figures in the answer would be meaningless.

Least-squares regression is often appropriate for situations where a straight-line relationship is not immediately obvious, for example, where $y \propto x^2$ or $y \propto \exp(x)$.

Example 8.2

From theoretical considerations, it is known that the voltage (V) across a charged capacitor decays with time (t) according to the relationship $V = K \exp(-t/\tau)$. Estimate values for K and t if the following values of V and t are measured.

V	8.67	6.55	4.53	3.29	2.56	1.95	1.43	1.04	0.78
e	0	1	2	3	4	5	6	7	6

Solution

If $V = K \exp(-T/\tau)$, then $\log_{x}(V) = \log_{x}(K) - t/\tau$. Now let $y = \log_{x}(V)$, $a = \log(K)$, band x = t. Hence, -a + bx, which is the equation of a straight line whose coefficients can estimated by applying Equations (8.5) and (8.6). Therefore, proceed in the same wall ab Example 8.1 and tabulate the values required:

~	tog.(V)	E .		
	(y) 216	(<i>π_i</i>)	(<i>x</i> _i <i>y</i> _i)	(z, ²)
8.67	1.88	1	1.88	1
4.53	1.51	2	3.02	4
1	1		E	
0.76	- 0.27		-2.16	

Now calculate the values needed from this table-n = 9; $\sum_{x,y_i} = 15.86$; $\sum_{x_i} = 204$, $x_m = 4.0$; $y_m = 0.9422$ -and enter these values into Equations (8.5) and (8.6).

$$= \frac{15.86 - (9 \times 4.0 \times 0.9422)}{204 - (9 \times 4.0^2)} = -0.301; \dot{a} = 0.9422 + (0.301 \times 4.0) = 2.15$$

$$K = \exp(a) = \exp(2.15) = 2.58; \tau = -1/b = -1/(-0.301) = 3.32$$

Quedrotic least squares regression

Quadratic least-squares regression is used to estimate the parameters of a relationship, $y = a + bx + cx^2$, between two sets of measurements, $y_1 \dots y_n$, $x_1 \dots x_n$.

The deviation of each point (x_i, y_i) from the line can be expressed as d_i , where $d_i = y_i - (a + bx_i + cx_i^2)$.

The best-fit line is obtained when the sum of the squared deviations, 5, is a minimum, that is, when

$$S = \sum_{i=1}^{n} (d_i^2) = \sum_{i=1}^{n} (y_i - a - bx_i + cx_i^2)^2$$

is a minimum.

The minimum can be found by setting the partial derivatives $\partial S/\partial a$, $\partial S/\partial b$, and $\partial S/\partial c$ to zero and setting the resulting simultaneous equations, as for the linear least-squares regression case are carrier. Standard computer programs to estimate the parameters a, b, and c by marcel methods are widely available and therefore a detailed solution is not presented here.

mynamed fint-Lauares regression

Polynomial last squares regression is used to estimate the parameters of the *p*th order relationship $x^2 + y_1 + y_2 + x_1$ between two sets of measurements, $y_1 + y_2 + x_1 + x_2$.

The deviation of each point (x_i, y_i) from the line can be expressed as d_i , where

$$d_i = y_i - (a_0 + a_1 x_i + a_2 x_i^2 + \dots + a_n x_i^n).$$

The best-fit line is obtained when the sum of squared deviations given by

$$S=\sum_{i=1}^{n}\left(d_{i}^{2}\right)$$

is a minimum.

The minimum can be found as before by setting p partial derivatives $\partial S/\partial a_0 \dots \partial S/\partial a_p$ to zero and solving the resulting simultaneous equations. Again, as for the quadratic least, squares regression case, standard computer programs to estimate the parameters $a_0 \dots a_p$ by numerical methods are widely available and therefore a detailed solution is not presented here.

Confidence tests in curve fitting by least-squares regression

Once data have been collected and a mathematical relationship that fits the data points has been determined by regression, the level of confidence that the mathematical relationship fitted is correct must be expressed in some way. The first check that must be made is whether the fundamental requirement for the validity of regression techniques is satisfied, that is, whether the deviations of data points from the fitted line are all less that the maximum error level predicted for the measured variable. If this condition is violated by any data point that a line or curve has been fitted to, then use of the fitted relationship is unsafe and recourse must be made to tabular data presentation, as described earlier,

The second check concerns whether random errors affect both measured variables. If attempts are made to fit relationships by regression to data where both measured variables contain random errors, any relationship fitted will only be approximate and it is likely that one or more data points will have a deviation from the fitted line or curve greater than the maximum error level predicted for the measured variable. This will show up when the appropriate checks are made.

Having carried out the aforementioned checks to show that there are no aspects of dam as suggest that regression analysis is not appropriate, the next step is to apply least-square regression to estimate the parameters of the chosen relationship (linear, quadratic, etc.). And this, some form of follow-up procedure is clearly required to assess how well the entitionship fits the data points. A simple curve-fitting confidence test is to calculate the squared deviations S for the chosen y/x relationship and compare it with the value of calculated for the next higher order regression curve that could be fitted to data. This is straight-line relationship is chosen, the value of S calculated should be of a similar memory.

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obtained by fitting a quadratic relationship. If the value of S were substantially lower a quadratic relationship, this would indicate that a quadratic relationship was a better fit to data than a straight-line one and further tests would be needed to examine whether a cubic or other order relationship was a better fit still.

more sophisticated confidence tests exist, such as the F-ratio test. However, these are enabled the scope of this book.

Correlation tests

Where both variables in a measurement data set are subject to random fluctuations, correlation is applied to determine the degree of association between the variables. For example, in the case already quoted of a data set containing measurements of human height and weight, we certainly expect some relationship between the variables of height and weight because a tall person is heavier on average than a short person. Correlation tests determine the averaget of the relationship (or interdependence) between the measured variables, which is expressed in the form of a correlation coefficient.

For two mass of measurements $y_1, \dots, y_n, x_1, \dots, x_n$ with means x_m and y_m , the correlation coefficient Φ is given by

$$\Phi = \frac{\sum (x_i - x_m)(y_i - y_m)}{\sqrt{\left[\sum (x_i - x_m)^2\right]\left[\sum (y_i - y_m)^2\right]}}$$

The value of tot always lies between 0 and 1, with 0 representing the case where the variables are completely independent of one another and 1 is the case where they are totally related to one mother. For 0 < 10 < 1, linear least-squares regression can be applied to indirelationships between the variables, which allows, to be predicted from a measurement of τ , and γ to be predicted from a measurement of τ . This involves finding two separate regression lines of the form:

$$y = a + hx$$
 and $x = c + dy$.

The two lines are not normally coincident. == shown in Figure 8.7. Both lines pass through the course of the data points but their slopes are different.

As int - 1, the lines tend to coincidence, representing the same where the two variables are their spondent on one another.

0, the lines tend to orthogonal ones parallel to the r and y axes. In this case, the two sets variables are tend to orthogonal ones parallel to the r and y axes. In this case, the two sets are variables are tend to independent. The best estimate of x given any measurement of x is x_{m} .





Figure 8.7 Relationship between two variables with random fluctuations.

For the general case, the best fit to data is the line that bisects the angle between the lines on Figure 8.7,

8.5 Summary

This chapter began by looking at the various ways that measurement data can be displayed, either using electronic display devices or using a computer monitor. We then went on to consider how measurement data could be recorded in a way that allows future analysis. We noted that this facility was particularly useful when faults develop in systems, as analysis of the changes in measured parameters in the time before the fault is discovered can often quick indicate the reason for the fault. Options available for recording data are numerous and inclusion chart recorders, digital oscilloscopes, digital data recorders, and hard-copy devices such as ink-jet and laser printers. We gave consideration to each of these and indicated some of the circumstances in which each alternative recording device might be used.

The next subject of study in the chapter was recommendations for good practice in the presentation of data. We looked at both graphical and tabular forms of presentation using either paper or a computer monitor screen as the display medium. We then went on to constant best way of fitting lines through data points on a graph. This led to a discussion of mathematic regression techniques and the associated confidence tests necessary to assess the correct the line fitted using regression. Finally, we looked at correlation tests. These are used to determine the degree of association between two aets of data when they are both subject and mathematical program.

8.6 Problems

- s 1. What are the main ways available for displaying parameter values to human operators responsible for controlling industrial manufacturing systems? (Discussion on electronic displays and computer monitors is expected.)
- 8.2 Discuss the range of instruments and techniques available for recording measurement signals, mentioning particularly the frequency response characteristics of each instrument or technique and the upper frequency limit for signals in each case.
- E3. Discuss the features of the main types of chart recorders available for recording measurement signals.
- 8.4. What is a digital data recorder and how does it work?
- 8.5. (a) Explain the derivation of the expression

$$\ddot{\Theta} + \frac{K_i^2 \Theta}{JR} + \frac{K_i \Theta}{J} = \frac{K_i V_i}{JR}$$

describing the dynamic response of a galvanometric chart recorder following a step change in the electrical voltage output of a transducer connected to its input. Explain also what all the terms is the expression stand for. (Assume that impedances of both the transducer and the recorder have a resistive component only and that there is negligible friction in the system.)

- (b) Derive expressions for the measuring system natural frequency, 10,, the damping factor, E, and the steady-state sensitivity.
- (c) Explain simple ways of increasing and decreasing the damping factor and describe the corresponding effect on measurement sensitivity,
- (d) What damping factor gives the best system bandwidth?
- (c) What aspects of the design of a chart recorder would you modify in order to improve the system bandwidth? What is the maximum bandwidth typically attainable is chart recorders, and if such a maximum bandwidth instrument is available, what is the highest frequency signal that such an instrument would be generally regarded as being suitable for measuring if the accuracy of the signal amplitude measurement is Important"
- 1.6. Discuss the relative merits of tabular and graphical methods of recording measurement data.
- 8.7. What would you regard as good practice in recording measurement data in graphical forma?
- What would you regard as good practice in recording measurement data in tabular form? Explain the technique of linear least-squares regression for finding a relationship

between two sets of measurement data. A 10. Explain the techniques of (a) quadratic least-squares regression and (b) polynomial least a surge regression. How would you determine whether either quadratic or

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polynomial least-squares regression provides a better fit to a set of measurement data than linear least-squares regression?

8.11. During calibration of a platinum resistance thermometer, the following temperature and resistance values were measured:

 Resistance (Q)
 212.8
 218.6
 225.3
 233.6
 240.8
 246.6

 Temperature (*C)
 300
 326
 340
 560
 380
 400

The temperature measurements were made using a primary reference standard instrument for which the measurement errors can be assumed to be zero. The resistance measurements were subject to random errors but it can be assumed that there are no systematic errors in them.

- (a) Determine the sensitivity of measurement in Ω/°C in as accurate a manner as possible.
- (b) Write down the temperature range that this sensitivity value is valid for.
- (c) Explain the steps that you would take to test the validity of the type of mathematical relationship that you have used for data.
- 8.12. Theoretical considerations show that quantities x and y are related in a linear fashion such that y = ax + b. Show that the best estimate of the constants a and b are given by

$$\hat{a} = \frac{\sum (x_i - x_m)(y_i - y_m)}{\sum (x_i - x_m)^2}$$
; $\hat{b} = y_m - \hat{a}x_m$

Explain carefully the meaning of all the terms in the aforementioned two equations.

8.13. The characteristics of a chromel-constantan thermocouple is known to be approximately linear over the temperature range of 300-800°C. The output e.m.f. was measured practically at a range of temperatures, and the following table of results was obtained. Using least-aquares regression, calculate coefficients a and b for the relationship T = a + bE that best describes the temperature -e.m.f. characteristic.

Temp (°C)	300	325	350	375	400	425	450	475	500	525	\$50
Lm.f. (mV)	21.0	23.2	25.0	26.9	28.6	31.3	32.8	35.0	37.2	38.5	40.7
Temp (*C)	575	600	623	650	675	700	725	750	775	800	
.m.f. (mV)	43.0	45.2	47.6	49.5	51.1	53.0	56.5	57.2	59.0	61.0	

8.14. Measurements of the current (I) flowing through a resistor and the corresponding voltage drop (V) are shown:

/ (amps) 1 2 3 4 5 V (volta) 10.6 20.4 30.7 40.5 50.0

Instruments used to measure voltage and current were accurate in all respects except the they each had a zero error that the observer failed to take account of or to correct a pretime of measurement. Determine the value of the resistor from data measured.

- 8.15. A measured quantity y is known from theoretical considerations to depend on variable x according to the relationship $y = a + bx^2$. For the following set of measurements of x and y, use linear least-squares regression to determine the estimates of parameters a and b that fit data best.
 - # 0 1 2 3 4 S y 0.9 9.2 33.4 72.5 130.1 200.6
- **5.16.** The mean time to failure (MTTF) of an integrated circuit is known to obey a law of the following form: $MTTF = C \exp T_0/T$, where T is the operating temperature and C and T_o are constants. The following values of MTTF at various temperatures were obtained from accelerated life tests.

M77F (hours) 54 105 206 411 941 2145 Temperature (*K) 680 580 560 540 520 500

- (a) Estimate the values of C and T_w [Hint: log_x(MTTF) = log_y(C) + T₀/T. This equation is now a straight-line relationship between log(MTTF) and UT, where log(C) and T_y, are constants.]
- (b) For an MTTF of 10 years, calculate the maximum allowable temperature,



CHAPTER 9

Variable Conversion Elements

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9.1 Introduction

We have already observed that outputs from measurement sensors often take the form of voltage signals. These can be measured using the voltage indicating and test instruments discussed in chapter 7. However, we have also discovered that sensor output does not take the form of an electrical voltage in many cases. Examples of these other forms of sensor output include translational displacements and changes in various electrical parameters such as resistance, inductance, capacitance, and current. In some cases, the output may alternatively take the form of variations in the phase or frequency of as a.c. electrical signal.

We therefore need to have a means of converting aensor outputs that are initially in some nonvoltage form into a more convenient form. This can be achieved by putting various types of variable conversion elements into the measurement system. We consider these in this chapter, First, we will see that bridge circuits are a particularly important type of variable conversion element; these are covered in some detail. Following this, we look at various alternative techniques for transducing the outputs of a measurement sensor into a form that is measured more readily.

9.2 Bridge Circuits

Bridge circuits are used very commonly as a variable conversion element in measurement systems and produce an output in the form of a voltage level that changes as the measured physical quantity changes. They provide an accurate method of measuring resistance, inductance, and capacitance values and enable the detection of very small changes in these quantities about a nominal value. They are of immense importance in measurement system technology because so many transducers measuring physical quantities have an output that is expressed as a change in resistance, inductance, or capacitance. A displacement-measuring strain gauge, which has a varying resistance output, is but one example of this class of transducers. Normally, excitation of the bridge is by a d.c. voltage for resistance measurement and by an a.c. voltage for inductance or capacitance measurement. Both null and deflection types of bridges exist, and, in a like meaner to instruments in general, null types are employed mainly for calibration purposes and deflection types are used within closed loop automatic control schemes.

9.2.1 Null-Type d.c. Bridge (Wheetstone Bridge)

A null-type bridge with d.c. excitation, known commonly as a Wheatstone bridge, has the form shown in Figure 9.1. The four arms of the bridge consist of the unknown resistance R_u , two equal value resistors R_2 and R_3 , and variable resistor R_4 (usually a decade resistance box). A d.c. voltage V_i is applied across the points AC, and resistance R_v is varied until the voltage measured across points BD is zero. This cull point is usually measured with a high sensitivity galvanometer.



To analyze the Whetstone bridge, define the current flowing in each arm to be $I_1 \ldots I_n$ as a shown in Figure 9.1. Normally, if a high impedance voltage-measuring instrument is used, current I_m drawn by the measuring instrument will be very small and can be approximated to zero. If this assumption is made, then, for $I_m = 0$; $I_1 = I_3$ and $I_2 = I_4$.

Looking at path ADC, we have voltage V, applied across resistance $R_1 + R_2$ and by Ohm's law:

$$I_1 = \frac{V_1}{R_* + R_3}$$

Similarly, for path ABC,

$$J_2 = \frac{V_i}{R_1 + R_2}.$$

Now we can calculate the voltage drop across AD and AB:

$$V_{AD} = l_1 R_r = \frac{V_r R_v}{R_v + R_3}$$
; $V_{AB} = l_2 R_r = \frac{V_r R_r}{R_r + R_3}$

By the principle of asperposition, $V_{\mu} = V_{BD} = V_{BA} + V_{AD} = -V_{AB} + V_{AD}$.

Thus,

$$V_{\mu} = -\frac{V_{\mu}R_{\mu}}{R_{\mu} + R_{2}} + \frac{V_{\mu}R_{\mu}}{R_{\mu} + R_{3}}.$$
(9.1)

At the null point $V_{-} = 0$, so

 $\frac{R_a}{R_a+R_3}=\frac{R_v}{R_v+R_2},$

 $\frac{R_a+R_3}{R_a}=\frac{R_r+R_2}{R_r}$

 $\frac{R_3}{R_m} = \frac{R_2}{R_r}$

Inverting both sides,

.

that is,

or

$$R_{\sigma} = \frac{R_3 R_{\tau}}{R_2}.$$
 (9.2)

Thus, if $R_2 = R_3$, then $R_u = R_v$. As R_v is an accurately known value because it is derived from a variable decade resistance box, this means that R_u is also accurately known.

A null-type bridge is somewhat todious to use as careful adjustment of variable resistance is needed to get exactly to the null point. However, it provides a highly accurate measurement of resistance, leading to this being the preferred type when sensors are being calibrated.

9.2.2 Deflection-Type d.c. Bridge

A deflection type bridge with d.c. excitation is shown in Figure 9.2. This differs from the Wheatstone bridge mainly in that variable resistance R_v is replaced by fixed resistance R_1 of the same value as the nominal value of unknown resistance R_u . As resistance R_u changes, so output voltage V_0 varies, and this relationship between V_0 and R_u must be calculated.

This relationship is simplified if we again assume that a high impedance voltage-measuring instrument is used and the current drawn by it, $I_{\rm am}$ can be approximated to zero. (The case when this assurantion does not hold is covered later in this section.) The analysis is then exactly the same as for the preceding example of the Whoststone bridge, except that R_i is replaced by R_1 . Thus, from Equation (9.1), we have



Deflection-type d.c. bridge.

$$V_0 = V_1 \left(\frac{R_*}{R_0 + R_3} - \frac{R_1}{R_1 + R_2} \right). \tag{9.3}$$

When R_n is at its nominal value, that is, for $R_n = R_1$, it is clear that $V_0 = 0$ (since $R_2 = R_3$). For other values of R_n , V_0 has negative and positive values that vary in a nonlinear way with R_n .

The inflection-type bridge is somewhat easier to use than a null-type bridge because the output measurement is given directly in the form of a voltage measurement. However, its measurement accuracy is not as good as that of a null-type bridge. Despite its inferior accuracy, case of use means that it is the preferred form of bridge in most general measurement situations unless the greater accuracy of a null-type bridge is absolutely necessary.

W Bample 9.1

A Detain type of pressure transducer, designed to measure pressures in the range D-10 consists of a diaphragm with a strain gauge cemented to it to detect diaphragm excloses. The strain gauge has a nominal resistance of 120 Ω and forms one arm of a Wheatstone bridge circuit, with the other three arms each having a resistance of 120 Ω are output is measured by an instrument whose input impedance can be assumed

infinite. If, in order to limit heating effects, the maximum permissible gauge current is 30 mA, calculate the maximum permissible bridge excitation voltage. If the sensitivity of the strain gauge is 338 m Ω /bar and the maximum bridge excitation voltage is used, calculate the bridge output voltage when measuring a pressure of 10 bar.

Solution

This is the type of bridge circuit shown in Figure 9.2 in which the components have the following values:

$$R_1 = R_2 = R_3 = 120 \ \Omega$$

Defining I, to be the current flowing in path ADC of the bridge, we can write

$$V_i = I_1(R_y + R_3).$$

At balance, $R_v = 120$ and the maximum value allowable for I_1 is 0.03A. Hence, $V_1 = 0.03$ (120 + 120) = 7.2 V. Thus, the maximum bridge excitation voltage allowable is 7.2 volts

For a pressure of 10 bar applied, the resistance change is 3.38Ω , that is, R_{μ} is then equal to 123.38 Ω . Applying Equation (9.3), we can write

$$V_8 = V_1 \left(\frac{R_u}{R_u + R_3} - \frac{R_1}{R_1 + R_2} \right) = 7.2 \left(\frac{123.38}{243.38} - \frac{120}{240} \right) = 50 \text{ mV}$$

Thus, if maximum permissible bridge excitation voltage is used, the output voltage is 50 mV when a pressure of 10 bar is measured.

The nonlinear relationship between output reading and measured quantity exhibited by Equation (9.3) is inconvenient and does not conform with the normal requirement for a linear input-output relationship. The method of coping with this nonlinearity varies according to the form of primary transducer involved in the measurement system.

One special case is where the change in unknown resistance R_u is typically small compared with the nominal value of R_u . If we calculate the new voltage V_0' when the resistance R_u in Equation (9.3) changes by an amount δR_u , we have

$$V_0 = V_l \left(\frac{R_s + \delta R_s}{R_s + \delta R_s + R_3} - \frac{R_1}{R_1 + R_2} \right). \tag{9.4}$$

The change of voltage output is therefore given by

$$\delta V_{R} = V_{0}' - V_{0} = \frac{V_{I} \delta R_{u}}{R_{u} + \delta R_{u} + R_{3}}.$$

If $AR_{\mu} < < R_{\mu}$ then the following linear relationship is obtained:

$$\frac{\delta V_0}{\delta R_n} = \frac{V_i}{R_n + R_3}.$$
(9.5)

This expression describes the measurement sensitivity of the bridge. Such an approximation to make the relationship linear is valid for transducers such as strain gauges where the typical biograms of resistance with strain are very small compared with nominal gauge resistance.

However, many instruments that are inherently linear themselves, at least over a limited measurement range, such as resistance thermometers, exhibit large changes in output as the input quantity changes, and the approximation of Equation (9.5) cannot be applied. In such cases, apecific action must be taken to improve linearity in the relationship between bridge output voltage and measured quantity. One common solution to this problem is to make the values of the resistances R_2 and R_1 at least 10 times those of R_1 and R_n (nominal). The effect of this is best observed by looking at a numerical example.

Consider a platinum resistance thermometer with a range of $0-50^{\circ}$ C whose resistance at 0°C is 500 Ω and whose resistance varies with temperature at the rate of 4 Ω /°C. Over this range of maximum rement, the output characteristic of the thermometer itself is nearly perfectly linear. (Note that the subject of resistance thermometers is discussed further in Chapter 14.)

Taking first the case where $R_1 = R_2 = R_3 = 500 \Omega$ and $V_i = 10 V$, and applying Equation (9.3);

At 0°C,
$$V_0 = 0$$

At 25°C, $R_n = 600 \ \Omega$ and $V_0 = 10 \left(\frac{600}{1100} - \frac{500}{1000} \right) = 0.455 \ V$
At 50°C, $R_n = 700 \ \Omega$ and $V_0 = 10 \left(\frac{700}{1200} - \frac{500}{1000} \right) = 0.833 \ V$

This relationship between V_0 and R_{μ} is plotted as curve A in Figure 9.3 and nonlinearity is apparent. Inspection of the manner in which output voltage V_0 above changes for equal steps of temperature change also clearly demonstrates nonlinearity.

For the temperature change from 0 to 25°C, the change in V_0 is $(0.455 - 0) = 0.455 \vee$ For the temperature change from 25 to 50°C, the change in V_0 is $(0.833 - 0.455) = 0.378 \vee$

If the relationship was linear, the change in V_0 for the 25-50 °C temperature step would also be 0.455 V, giving a value for V_0 of 0.910 V at 50 °C.

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Chromel-constantan thermocouples (type E) give the highest measurement sensitivity of $68 \mu V/°C$, with an inaccuracy of $\pm 0.5\%$ and a useful measuring range of -200°C up to 900°C. Unfortunately, while they can operate satisfactorily in oxidizing environments when unprotected their performance and life are seriously affected by reducing atmospheres.

Iron-constantan thermocouples (type J) have a sensitivity of 55 μ V/°C and are the preferred type for general-purpose measurements in the temperature range of -40 to +750°C, where the typical measurement inaccuracy is ±0.75%. Their performance is little affected by either oxidizing or reducing atmospheres.

Copper-constantan thermocouples (type T) have a measurement sensitivity of 43 μ V/C and find their main application in measuring subzero temperatures down to -200°C, with an inaccuracy of ±0.75%. They can also be used in both oxidizing and reducing atmospheres to measure temperatures up to 350°C.

Chromel-alumel thermocouples (type K) are widely used, general-purpose devices with a measurement sensitivity of 41 μ V/°C. Their output characteristic is particularly linear over the temperature range between 700 and 1200°C and this is therefore their main application, although their full measurement range is -200 to +1300°C. Like chromel-constantan devices, they are suitable for oxidizing atmospheres but not for reducing ones unless protected by a sheath. Their measurement inaccuracy is ±0.75%.

Nicrosil-nisil thermocouples (type N) were developed with the specific intention of improving on the lifetime and stability of chromel-alumel thermocouples. They therefore have similar thermoelectric characteristics to the latter but their long-term stability and life are at least three times better. This allows them to be used in temperatures up to 1300° C. Their measurement sensitivity is 39 μ V/°C and they have a typical measurement uncertainty of ±0.75%. A detail comparison between type K and N devices can be found in Brooks (1985).

Nickelimolybdenum-nickel-cobalt thermocouples (type M) have one wire made from a nickelmolybdenum alloy with 18% molybdenum and the other wire made from a nickel-cobalt alloy with 0.8% cobalt. They can measure at temperatures up to 1400°C, which is higher than other types of base metal thermocouples. Unfortunately, they are damaged in both oxidizing and reducing atmospheres. This means that they are rarely used except for specim applications such as temperature measurement in vacuum furnaces.

Noble metal thermocouples are expensive, but they enjoy high stability and long life even when used at high temperatures, although they cannot be used in reducing atmospheres. Unfortunately, their measurement sensitivity is relatively low. Because of this, their use is mainly restricted to measuring high temperatures unless the operating environment particularly aggressive in low-temperature applications. Various combinations of the metaplatinum and tungsten and the metal alloys of platinum-rhodium, tungsten-rhenium, and gold-iron are used. thermocouples (type B) have one wire made from a platinum-rhodium alloy with 00% rhodium and the other wire made from a platinum-rhodium alloy with 6% rhodium. There were a measuring range is ± 50 to ± 1800 C, with a measurement sensitivity of 10 μ V/C.

Platinum thermocouples (type R) have one wire made from pure platinum and the other wire made from a platinum-rhodium alloy with 13% rhodium. Their quoted measuring 0 to $\pm 1700^{\circ}$ C, with a measurement sensitivity of 10 μ V/C and quoted inaccuracy of $\pm 0.5\%$

thermocouples (type S) have one wire made from pure platinum and the other from a platinum-thodium alloy with 10% rhodium. They have similar characteristics to type R devices, with a quoted measuring range of 0 to ± 1750 C, measurement sensitivity of 10 μ V/C, and inaccuracy of $\pm 0.5\%$.

Tungsten thermocouples (type C) have one wire made from pure tungsten and the other wire made from a tungsten/rhenium alloy. Their measurement sensitivity of 20 μ V/°C is double that of platinum thermocouples, and they can also operate at temperatures up to 2300°C. Unfortunately, they are damaged in both oxidizing and reducing atmospheres. Therefore, their main application is temperature measurement in vacuum furnaces.

Chromal-gold/iron thermocouples have one wire made from chromel and the other wire made from a gold/iron alloy which is, in fact, almost pure gold but with a very small iron content (typically 0.15%). These are rare, special-purpose thermocouples with a typical measurement sensitivity of 15 μ V/°K designed specifically for cryogenic (very low temperature) applications. The lowest temperature measureable is 1.2°K. Several versions are available, which differ according to the iron content and consequent differences in the measurement range and sensitivity. Because of this variation in iron content, and also because of their rarity, these do not have an international type letter.

14.2.4 Mermocouple Protection

The new place are delicate devices that must be treated carefully if their specified operating induced strain in the hot this reduces the e.m.f. output, and precautions are normally taken to minimize strain by mounting the thermocouple horizontally rather than vertically. It is usual to cover most of the thermocouple wire with thermal insulation, which also provides mechanical strain, although the tip is left exposed if possible to maximize the speed of response to changes in the measured temperature. However, thermocouples are prone to contamination in strain systemating environments. This means that their e.m.f./temperature characteristic shortens they life.

Material	Maximum Operating Temperature ("C)
Mild steel	900
Nickel-chromium	900
Fused shca	1000
Special steel	1100
Mullite	1700
Recrystallized alumina	1850
Beryllia	\$ 2300
Magnesia	2400
Zicronia	2400
Thona	2600

Table 14.1 Common Sheath Materials for Thermocouples

The contrast operating temperatures quoted assume condumg or neutral atmospheres. For operation in reducing atmosphere, the maximum allowable temperature is usually reduced.

Where they are prone to contamination, thermocouples have to be protected by enclosing them, entirely in an insulated sheath. Some common sheath materials and their maximum operating temperatures are shown in Table 14.1. While the thermocouple is a device that has a naturally first-order type of step response characteristic, the time constant is usually so small as to be negligible when the thermocouple is used unprotected. However, when enclosed in a sheath the time constant of the combination of thermocouple and sheath is significant. The size of the thermocouple and hence the diameter required for the sheath have a large effect on the importance of this. The time constant of a thermocouple in a 1-mm-diameter sheath is only 0.15 s and this has little practical effect in most measurement situations, whereas a larger sheath of 6 mm diameter gives a time constant of 3.9 s that cannot be ignored so easily.

14.2.5 Thermocouple Manufacture

Thermocouples are manufactured by connecting together two wires of different materials, where each material is produced so as to conform precisely with some defined composition specification. This ensures that its thermoelectric behavior accurately follows that for which standard thermocouple tables apply. The connection between the two wires is affected by welding, soldering, or, in some cases, just by twisting the wire ends together. Welding is the mode common technique used generally, with silver soldering being reserved for copper-constant devices.

The diameter of wire used to construct thermocouples is usually in the range between 0.4 and 2 mm. Larger diameters are used where ruggedness and long life are required, although these advantages are gained at the expense of increasing the measurement time constant. In the case of noble metal thermocouples, the use of large diameter wire incurs a substantial compensity. Some special applications have a requirement for a very fast response time in the measurement of temperature, and in such cases wire diameters as small as $0.1 \ \mu m$ can be used.

14.2.6 Thermopile

The themopile is the name given to a temperature-measuring device that consists of several democratives connected together in series, such that all the reference junctions are at the momentum and all the hot junctions are exposed to the temperature being measured, as shown in figure 14.7. The effect of connecting *n* thermocouples together in series is to increase the measurement sensitivity by a factor of *n*. A typical thermopile manufactured by increase the measurement resolution of 0.001°C

14 2.7 Digital Thermometer

Thermitaliple are also used in digital thermometers, of which both simple and intelligent exists (for a description of the latter, see Section 14.12). A simple digital thermometer a combination of a thermocouple, a battery-powered, dual-slope digital voltmeter to measure the thermocouple output, and an electronic display. This provides a low noise, digital output that can resolve temperature differences as small as 0.1 C. The accuracy achieved is dependent on the accuracy of the thermocouple element, but reduction of measurement inaccuracy to $\pm 0.5\%$ is achievable.

14.2.8 Cantinuous Thermocouple

The continuous thermocouple is one of a class of devices that detect and respond to heat. Other devices in this class include the *line-type heat detector* and *heat-sensitive cable*. The basic analyzection of all these devices consists of two or more strands of wire separated by insulation within a long thin cable. While they sense temperature, they do not in fact provide an output remainment of temperature. Their function is to respond to abnormal temperature tises and thus prevent fires, equipment damage, etc.



The advantages of continuous thermocouples become more apparent if problems with other types of heat detectors are considered. Insulation in the line-type heat detector and heat-sensitive cable consists of plastic or ceramic material with a negative temperature coefficient (i.e., the resistance falls as the temperature rises). An alarm signal can be generated when the measured resistance falls helow as certain level. Alternatively, in some versions, the insulation of these devices is that the temperature change has to be relatively large, typically 50–200°C above ambient temperature, before the device responds. Also, it is not generally possible for such devices to give an output that indicates that an alarm condition is developing before it actually happens, and thus allow preventative action. Furthermore, after the device has generated an alarm it usually has to be replaced. This is particularly inknome because there is a large variation in the characteristics of detectors coming from different batches and so replacement of the device requires extensive onsite recalibration of the system.

In contrast, the continuous thermocouple suffers from very few of these problems. It differs from other types of heat detectors in that the two strands of wire inside it are a pair of thermocouple materials separated by a special, patented mineral insulation and contained within a stainless-steel protective sheath. If any part of the cable is subjected to heat, the resistance of the insulation at that point is reduced and a "hot junction" is created between the two wires of dissimilar metals. An e.m.f. is generated at this hot junction according to normal thermoelectric principles.

The continuous thermocouple can detect temperature rises as small as 1°C above normal. Unlike other types of heat detectors, it can also monitor abnormal rates of temperature rise and provide a warning of alarm conditions developing before they actually happen. Replacement is only necessary if a great degree of insulation breakdown has been caused by a substantial hot spot at some point along the detector's length. Even then, the use of thermocouple materials of standard characteristics in the detector means that recalibration is not needed if it is replaced. Because calibration is not affected either by cable length, a replacement cable may be of a different length to the one it is replacing. One further advantage of continuous thermocouples over earlier forms of heat detectors is that no power supply is needed, thus significantly reducing installation costs.

14.3 Varying Resistance Devices

Varying resistance devices rely on the physical principle of the variation of resistance with temperature. The devices are known as either resistance thermometers or thermistors according to whether the material used for their construction is a metal or a semiconductor, and both are common measuring devices. The normal method of measuring resistance is to use a d.c. bridge. The excitation voltage of the bridge has to be chosen very carefully because, although a high value is desirable for achieving high measurement sensitivity.

^{*} Normally type E, chromel -constantan, or type K, chromel -alumel
the self-iscating effect of high currents flowing in the temperature transducer creates an error by increasing the temperature of the device and so changing the resistance value.

Resistance Thermometers (Resistance Temperature Devices)

Resistance thermometers, which are alternatively known as *resistance temperature devices*, say on the principle that the resistance of a metal varies with temperature according to the relationship:

$$R = R_0(1 + a_1T + a_2T^2 + a_3T^3 + \dots + a_nT^n).$$
(14.7)

This equation is nonlinear and so is inconvenient for measurement purposes. The equation becomes linear if all the terms in a_2T^2 and higher powers of T are negligible such that the residence and temperature are related according to

$$R \approx R_0(1 + a_1T).$$

This equation is approximately true over a limited temperature range for some metals, notably platinum, copper, and nickel, whose characteristics are summarized in Figure 14.8. Platinum has the most linear resistance/temperature characteristic and also has good chemical inertness. It is therefore far more common than copper or nickel thermocouples. Its resilinace-temperature relationship is linear within $\pm 0.4\%$ over the temperature range between -200 and $\pm 40^{\circ}$ C. Even at $\pm 1000^{\circ}$ C, the quoted inaccuracy figure is only $\pm 1.2\%$. Platinum thermometers are made in three forms, as a film deposited on a ceramic substrate, as a coil mounted inside a glass or ceramic probe, or as a coil wound on a mandrel, although the last of these are now becoming rare. The nominal resistance at 0° C is typically 100 or 1000 Ω , although 200 and 500 Ω versions also exist. Sensitivity is 0.385 Ω/C (100 Ω type) or 3.85 Ω/C (1000 Ω type). A high nominal resistance is advantageous in terms of higher measurement sensitivity, and the resistance of connecting leads has less effect on measurement accuracy. However, cost goes up as the nominal resistance increases.

In addition to having a less linear characteristic, both nickel and copper are inferior to platinum in terms of their greater susceptibility to oxidation and corrosion. This seriously limits their occuracy and longevity. However, because platinum is very expensive compared to nickel and the latter are used in resistance thermometers when cost is important. Another metal, also used in resistance thermometers in some circumstances, particularly for high rature measurements. The working ranges of each of these four types of resistance thermometers are as shown here:

Platinum: -270 to +1000 C (although use above 650° C is uncommon) Copper: -200 to +260° C Nickel: -200 to +430° C Tingsten: -270 to +1100° C

The advantages of continuous thermocouples become more apparent if problems with other types of heat detectors are considered. Insulation in the line-type heat detector and heat-sensitive cable consists of plastic or ceramic material with a negative temperature coefficient (i.e., the resistance falls as the temperature rises). An alarm signal can be generated when the measured resistance falls below a certain level. Alternatively, in some versions, the insulation is allowed to break down completely, in which case the device acts as a switch. The major limitation of these devices is that the temperature change has to be relatively large, typically $50-200^{\circ}$ C above ambient temperature, before the device responds. Also, it is not generally possible for such devices to give an output that indicates that an alarm condition is developing before it actually happens, and thus allow preventative action. Furthermore, after the device has generated an alarm it usually has to be replaced. This is particularly inksome because there is a large variation in the characteristics of detectors coming from different batches and so replacement of the device requires extensive onsite recalibration of the system.

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This equation is nonlinear and so is inconvenient for measurement purposes. The equation becomes linear if all the terms in a_2T^2 and higher powers of T are negligible such that the resistance and temperature are related according to

$$R \approx R_0(1 + a_1T).$$

This equation is approximately true over a limited temperature range for some metals, notably platinum, copper, and nickel, whose characteristics are summarized in Figure 14.8. Platinum has the most linear resistance/temperature characteristic and also has good chemical inertness. It is therefore far more common than copper or nickel thermocouples. Its resistance-temperature relationship is linear within $\pm 0.4\%$ over the temperature range between -200 and $\pm 40^{\circ}$ C. Even at $\pm 1000^{\circ}$ C, the quoted inaccuracy figure is only $\pm 1.2\%$. Platinum thermometers are made in three forms, as a film deposited on a ceramic substrate, as a coil mounted inside a glass or ceramic probe, or as a coil wound on a mandrel, although the last of these are now becoming rare. The nominal resistance at 0 C is typically 100 or 1000 Ω , although 200 and 500 Ω versions also exist. Sensitivity is 0.385 Ω/C (100 Ω type) or 3.85 Ω/C (1000 Ω type) or 3.85 Ω/C (1000 Ω type). A high nominal resistance is advantageous in terms of higher measurement sensitivity, and the resistance of connecting leads has less effect on measurement accuracy. However, cost goes up as the nominal resistance increases.

In addition to having a less linear characteristic, both nickel and copper are inferior to platinum in terms of their greater susceptibility to oxidation and corrosion. This seriously limits their curacy and longevity. However, because platinum is very expensive compared to nickel and copper, the latter are used in resistance thermometers when cost is important. Another metal, also used in resistance thermometers in some circumstances, particularly for high perature measurements. The working ranges of each of these four types of resistance hermometers are as shown here:

Platinum: -270 to +1000 C (although use above 650 C is uncommon) Copper: -200 to +260°C Nickel: -200 to +430°C Tunesten: -270 to +1100°C



Typical resistance-temperature characteristics of metals.

In the case of noncorrosive and nonconducting environments, resistance thermometers are used without protection. In all other applications, they are protected inside a sheath. As in the case of thermocouples, such protection reduces the speed of response of the system to rapid changes in temperature. A typical time constant for a sheathed platinum resistance thermometer is 0.4 seconds. Moisture buildup within the sheath can also impair measurement accuracy.

The frequency at which a resistance thermometer should be calibrated depends on the material it is made from and on the operating environment. Practical experimentation is therefore needed to determine the necessary frequency and this must be reviewed if the operating conditions change.

14.3.2 Thermistors

Thermistors are manufactured from beads of semiconductor material prepared from oxides of the iron group of metals such as chromium, cobalt, iron, manganese, and nickel. Normally, thermistors have a negative temperature coefficient, that is, resistance decreases as temperature increases, according to:

$$R = R_{00} [\beta (1/T - 1/T_0)]$$
(14.8)

The relationship is illustrated in Figure 14.9. However, alternative forms of heavily doped in mistors are now available (at greater cost) that have a positive temperature coefficient. The form of Equation (14.8) is such that it is not possible to make a linear approximation to the curve over even a small temperature range, and hence the thermistor is very densitely a nonlinear sensor. However, the major advantages of thermistors are their relatively and their small size. This size advantage means that the time constant of thermistors while and their small, although the size reduction also decreases its heat dissipation while and a makes the self-heating effect greater. In consequence, thermistors have be operated at generally lower current levels than resistance thermometers and so the errent sensitivity is less.



Typical resistance-temperature characteristics of thermistor materials.

As in the case of resistance thermometers, some practical experimentation is needed to determine the necessary frequency at which a thermistor should be calibrated and this must be reviewed if the operating conditions change.

14.4 Semiconductor Devices

Semiconductor devices, consisting of either diodes or integrated circuit transistors, have only been commonly used in industrial applications for a few years, but they were first invented several decades ago. They have the advantage of being relatively inexpensive, but one difficulty that affects their use is the need to provide an external power supply to the sensor.

Integrated circuit transistors produce an output proportional to the absolute temperature. Different types are configured to give an output in the form of either a varying current (typically 1 μ A K) or a varying voltage (typically 10 mV°K). Current forms are normally used with a digital voltmeter that detects the current output in terms of the voltage drop across a 10-K Ω resistor. Although the devices have a very low cost (typically a few dollars) and a better linearity than either thermocouples or resistance thermometers, they only have a limited measurement range from -50 to +150°C. Their inaccuracy is typically $\pm 3\%$, which limits their range of application. However, they are widely used to monitor pipes and cables, where their low cost means that it is feasible to mount multiple sensors along the length of the pipe/cable to detect hot spots.

In diodes, the forward voltage across the device varies with temperature. Output from a typical diode package is in the microamp range. Diodes have a small size, with good output linearity and typical inaccuracy of only $\pm 0.5\%$. Silicon diodes cover the temperature range from -50 to $+200^{\circ}$ C and germanium ones from -270 to $+40^{\circ}$ C.

14.5 Radiation Thermometers

All objects emit electromagnetic radiation as a function of their temperature above absolute zero, and radiation thermometers (also known as radiation pyrometers) measure this radiation in order to calculate the temperature of the object. The total rate of radiation emission per second is given by

$$\mathcal{E} = KT^4. \tag{14.9}$$

The power spectral density of this emission varies with temperature in the manner shown in Figure 14.10. The major part of the frequency spectrum lies within the band of wavelengths between 0.3 and 40 μ m, which corresponds to visible (0.3–0.72 μ m) and infrared (0.72–1000 μ m) ranges. As the magnitude of the radiation varies with temperature, measurement of the emission from a body allows the temperature of the body to be calculated. Choice of the bar method of measuring the emitted radiation depends on the temperature of the body. At lot temperatures, the peak of the power spectral density function (Figure 14.10) lies in the





intered region, whereas at higher temperatures it moves toward the visible part of the strum. This phenomenon is observed as the red glow that a body begins to emit as its temperature is increased beyond 600°C.

The theorem is the term of term o

of temperature-measuring instruments is that there is no contact with the hot body while its temperature is being measured. Thus, the measured system is not disturbed in any way. Furthermore, there is no possibility of contamination, which is particularly important in food, drug, and many other process industries. They are especially suitable for measuring high temperatures beyond the capabilities of contact instruments such as thermocouples. resistance thermometers, and thermistors. They are also capable of measuring moving bodies for instance, the temperature of steel bars in a rolling mill. Their use is not as straightforward as the discussion so far might have suggested, however, because the radiation from a body varies with the composition and surface condition of the body, as well as with temperature This dependence on surface condition is quantified by the *emissivity* of the body. The use of radiation thermometers is further complicated by absorption and scattering of the energy between the emitting body and the radiation detector. Energy is scattered by atmospheric dust and water droplets and is absorbed by carbon dioxide, ozone, and water vapor molecules. Therefore, all radiation thermometers have to be calibrated carefully for each particular body whose temperature they are required to monitor.

Various types of radiation thermometers exist, as described next. The optical pyrometer can only be used to measure high temperatures, but various types of radiation pyrometers are available that, between them, cover the whole temperature spectrum. Intelligent versions (see Section 14.12) also now provide full or partial solutions to many of the problems described later for nonintelligent pyrometers.

14.5.1 Optical Pyrometer

The optical pyrometer, illustrated in Figure 14.11, is designed to measure temperatures where the peak radiation emission is in the red part of the visible spectrum, that is, where the measured body glows a certain shade of red according to the temperature. This limits the instrument to measuring temperatures above 600°C. The instrument contains a heated tungsten filament within its optical system. The current in the filament is increased until its color is the same as the hot body: under these conditions the filament apparently disappears when viewed against the background of the hot body. Temperature measurement is therefore obtained in terms of the current flowing in the filament. As the brightness of different materials at any particular temperature varies according to the emissivity of the material, the calibration of the optical pyrometer must be adjusted according to the emissivity of the target. Manufacturers provide tables of standard material emissivities to assist with this.

The inherent measurement inaccuracy of an optical pyrometer is $\pm 5^{\circ}$ C. However, in addition to this error, there can be a further operator-induced error of $\pm 10^{\circ}$ C arising out of the difficulty in judging the moment when the filament "just" disappears. Measurement accuracy can be improved somewhat by employing an optical filter within the instrument that passes a narroband of frequencies of wavelength around 0.65 µm corresponding to the red part of the visible



Figure 14.11 Optical pyrometer.

ngestrum. This also extends the upper temperature measurable from 5000°C in unfiltered instatements up to 10,000°C

The instrument cannot be used in automatic temperature control schemes because the eye of the human operator is an essential part of the measurement system. The reading is also affected by fames in the sight path. Because of these difficulties and its low accuracy, hand-held radiation pyrometers are rapidly overtaking the optical pyrometer in popularity, although the information is still widely used in industry for measuring temperatures in furnaces and similar applications at present.

14.5.2 Rediation Pyrometers

All the phermative forms of radiation pyrometers described here have an optical system similar to that of the optical pyrometer and focus the energy emitted from the measured body. However, they differ by omitting the filament and eyepiece and having instead an energy detector in the same focal plane as the eyepiece was, as shown in Figure 14.12. This principle is to measure temperature over a range from -100 to +3600 °C. The radiation detector a thermal detector, which measures the temperature rise in a black body at the focal the optical system, or a photon detector.

detectors respond equally to all wavelengths in the frequency spectrum and consist of the resistance thermometers, or thermistors. All of these typically have time constants milliseconds because of the time taken for the black body to heat up and the sensor to respond to the temperature change.



Photon detectors respond selectively to a particular band within the full spectrum and are usually of the photoconductive or photovoltaic type. They respond to temperature changes much faster than thermal detectors because they involve atomic processes, and typical measurement time constants are a few microseconds.

Fiber-optic technology is used frequently in high temperature measurement applications to collect the incoming radiation and transmit it to a detector and processing electronics that are located remotely. This prevents exposure of the processing electronics to potentially damagine high temperature. Fiber-optic cables are also used to apply radiation pyrometer principles in very difficult applications, such as measuring the temperature inside jet engines by collecting the radiation from inside the engine and transmitting it outside (see Section 14.9).

The size of objects measured by a radiation pyrometer is limited by the optical resolution, which is defined as the ratio of target size to distance. A good ratio is 1:300, which would alloc temperature measurement of a 1-mm-sized object at a range of 300 mm. With large distance target size ratios, accurate aiming and focusing of the pyrometer at the target are essential. It is now common to find "through the lens" viewing provided in pyrometers, using a principle similar to SLR camera technology, as focusing and orientating the instrument for visible lift focuses it automatically for infrared light. Alternatively, dual laser beams are sometimes used to ensure that the instrument is aimed correctly toward the target.

Various forms of electrical output are available from the radiation detector: these are functions of the incident energy on the detector and are therefore functions of the temperature of the measured body. While this therefore makes such instruments of use in automatic control systems, their accuracy is often inferior to optical pyrometers. This reduced accuracy arises for because a radiation pyrometer is sensitive to a wider band of frequencies than the optical instrument and the relationship between emitted energy and temperature is less well defined. Second, the magnitude of energy emission at low temperatures gets very small, according to Equation (14.9), increasing the difficulty of accurate measurement.

The forms of radiation pyrometer described here differ mainly in the technique used to measure the emitted radiation. They also differ in the range of energy wavelengths, and hence the temperature range, which each is designed to measure. One further difference is the material because almost opsque to infrared wavelengths, and other lens materials such as arsenic prisulfide are used.

(unchopped) radiation pyrometers

band radiation pyrometer finds wide application in industry and has a measurement that varies from $\pm 0.05\%$ of full scale in the best instruments to $\pm 0.5\%$ in the least However, their accuracy deteriorates significantly over a period of time, and an error is common after 1-2 years operation at high temperatures. As its name implies, the measures radiation across the whole frequency spectrum and so uses a thermal. This consists of a blackened platinum disc to which a thermopile is bonded. The of the detector increases until the heat gain from the incident radiation is balanced by the beat loss due to convection and radiation. For high-temperature measurement, a two constitutermopile gives acceptable measurement sensitivity and has a fast time constant of about 0.1 s. At lower measured temperatures, where the level of incident radiation is much less, thermopiles constructed from a greater number of thermocouples must be used to get sufficient measurement mensitivity. This increases the measurement time constant to as much as 2 s. Standard instruments of this type are available to measure temperatures between -20 and $\pm 1800\%$, although much higher temperatures in theory could be measured by this method.

Chapped broad band radiation pyrometers

Construction of this form of pyrometer is broadly similar to that shown in Figure 14.12 except that a rotary mechanical device is included that periodically interrupts the radiation reaching the detector. The voltage output from the thermal detector thus becomes an alternating quantity that switches between two levels. This form of a.c. output can be amplified much more readily than the d.c. output coming from an unchopped instrument. This is particularly important when amplification is necessary to achieve an acceptable measurement resolution in situations where the level of incident radiation from the measured body is low. For this reason, this form of instrument is the more common when measuring body temperatures associated with peak emission in the infrared part of the frequency spectrum. For such chopped systems, the time of thermopiles is too long. Instead, thermistors are generally used, giving a time constant e^{o} 0.01 s. Standard instruments of this type are available to measure temperatures hetwom ± 20 and $\pm 1300^{\circ}$ C. This form of pyrometer suffers similar accuracy drift to inchopped forms. Its life is also limited to about 2 years because of motor failures.

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Narrow band radiation pyrometers

Narrow-band radiation pyrometers are highly stable instruments that suffer a drift in accuracy that is typically only 1°C in 10 years. They are also less sensitive to emissivity changes than other forms of radiation pyrometers. They use photodetectors of either the photoconductive or the photovoltaic form whose performance is unaffected by either carbon dioxide or water vapor in the path between the target object and the instrument A photoconductive detector exhibits a change in resistance as the incident radiation level changes, whereas a photovoltaic cell exhibits an induced voltage across its terminals that is also a function of the incident radiation level. All photodetectors are preferentially sensitive to a particular narrow band of wavelengths in the range of $0.5 - 1.2 \mu$ m and all have a form of output that varies in a highly nonlinear fashion with temperature, and thus a microcomputer inside the instrument is highly desirable. Four commonly used materials for photodetectors are cadmum sulfide, lead sulfide, indium antimonide, and lead tin telluride. Each of these is sensitive to a different band of wavelengths and therefore all find application in measuring the particular temperature ranges corresponding to each of these bands.

Output from the narrow band radiation pyrometer is normally chopped into an a.c. signal in the same manner as used in the chopped broad-band pyrometer. This simplifies amplification of the output signal, which is necessary to achieve an acceptable measurement resolution. The typical time constant of a photon detector is only 5 µs, which allows high chopping frequencies up to 20 kHz. This gives such instruments an additional advantage in being able to measure fast transients in temperature as short as 10 µs.

Two-color pyrometer (ratio pyrometer)

As stated earlier, the emitted radiation-temperature relationship for a body depends on its emissivity. This is very difficult to calculate, and therefore in practice all pyrometers have to be calibrated to the particular body they are measuring. The two-color pyrometer (alternatively known as a ratio pyrometer) is a system that largely overcomes this problem by using the arrangement shown in Figure 14.13. Radiation from the body is split equally into two partwhich are applied to separate narrow-band filters. Outputs from the filters consist of radiaties within two narrow bands of wavelengths λ_1 and λ_2 . Detectors sensitive to these frequence produce output voltages V_1 and V_2 , respectively. The ratio of these outputs, (V_1/V_2) , can be shown (see Dixon, 1987) to be a function of temperature and to be independent of emissivity provided that the two wavelengths, λ_1 and λ_2 , are close together.

The theoretical basis of the two-color pyrometer is that output is independent of emissivity because emissivities at the two wavelengths λ_1 and λ_2 are equal. This is based on the assumption that λ_1 and λ_2 are very close together. In practice, this assumption does not hold and therefore the accuracy of the two-color pyrometer tends to be relatively poor. However, the instrument is still of great use in conditions where the target is obscured by fumes or dust, which is a communication of the two color pyrometer tends to be relatively poor.



Two-color pyrometer system.

problem in the cement and mineral processing industries. Two-color pyrometers typically cost 51 - 100% more than other types of pyrometers.

Selected moveband pyrometer

The selected waveband pyrometer is sensitive to one waveband only, for example, 5 µm, and is dedicated to particular, special situations where other forms of pyrometers are inaccurate. One example of such a situation is measuring the temperature of steel billets being heated in a furnace. If an ordinary radiation pyrometer is aimed through the furnace door at a hot billet, it receives indiation from the furnace walls (by reflection off the billet) as well as radiation from the hillet itself. If the temperature of the furnace walls is measured by a thermocouple, a correction can be made for the reflected radiation, but variations in transmission losses inside the furnace through furnes and so on make this correction inaccurate. However, if a carefully chosen selected waveband pyrometer is used, this transmission loss can be minimized and the measurement accuracy is thereby improved greatly.

14.6 mermography (Thermal Imaging)

Thermography, or thermal imaging, involves scanning an infrared radiation detector across object. The information gathered is then processed and an output in the form of the temperature distribution across the object is produced. Temperature measurement over the -20 C up to +1500 C is possible. Elements of the system are shown in

of the infrared radiation. However, instead of providing a measurement of the



Thermography (thermal imaging) system.

temperature of a single point at the focal point of the instrument, the detector is scanned across a body or scene, and thus provides information about temperature distributions. Because of the scanning mode of operation of the instrument, radiation detectors with a very fast response are required, and only photoconductive or photovoltaic sensors are suitable. These are sensitive to the portion of the infrared spectrum between wavelengths of 2 and 14 µm.

Simpler versions of thermal imaging instruments consist of hand-held viewers that are pointed at the object of interest. The output from an array of infrared detectors is directed onto a matrix of red light-emitting diodes assembled behind a glass screen, and the output display thus consists of different intensities of red on a black background, with the different intensities corresponding to different temperatures. Measurement resolution is high, with temperature differences as small as 0.1°C being detectable. Such instruments are used in a wide variety of applications, such as monitoring product flows through pipe work, detecting insulation faults, and detecting hot spots in furnace linings, electrical transformers, machines, bearing etc. The number of applications is extended still further if the instrument is carried in a helicopter, where uses include scanning electrical transmission lines for faults, searching for lost or injured people, and detecting the source and spread pattern of forest fires.

More complex thermal imaging systems comprise a tripod-mounted detector connected to a desktop computer and display system. Multicolor displays are used commonly in such system, where up to 16 different colors represent different bands of temperature across the measured range. The heat distribution across the measured body or scene is thus displayed graphically as contoured set of colored bands representing the different temperature levels. Such color thermography systems find many applications, such as inspecting electronic circuit boards and monitoring production processes. There are also medical applications in body scanning.

Thermal Expansion Methods

Thermal expansion methods make use of the fact that the dimensions of all substances, whether big discuids, or gases, change with temperature. Instruments operating on this physical musicle include the liquid-in-glass thermometer, bimetallic thermometer, and pressure thermometer.

14.7.1 Liquid-in-Glass Thermometers

tiouid-in-glass thermometer is a well-known temperature-measuring instrument used in a wide range of applications. The fluid used is normally either mercury or colored alcohol, which is contained within a bulb and capillary tube, as shown in Figure 14.15a. As the temperature nees, the fluid expands along the capillary tube and the meniscus level is read against a calibrated scale etched on the tube. Industrial versions of the liquid-in-glass thermometer are



and (c) pressure thermometer. (b) bimetallic thermometer.

normally used to measure temperature in the range between -200 and +1000°C, although instruments are available to special order that can measure temperatures up to 1500°C.

Measurement inaccuracy is typically $\pm 1\%$ of full-scale reading, although an inaccuracy of only $\pm 0.15\%$ can be achieved in the best industrial instruments. The major source of measurement error arises from the difficulty of correctly estimating the position of the curved meniscus of the fluid against the scale. In the longer term, additional errors are introduced due to volumetric changes in the glass. Such changes occur because of creep-like processes in the glass, but occur only over a timescale of years. Annual calibration checks are therefore advisable.

14.7.2 Bimetallic Thermometer

The bimetallic principle is probably more commonly known in connection with its use in thermostats. It is based on the fact that if two strips of different metals are bonded together, any temperature change will cause the strip to bend, as this is the only way in which the differing rates of change of length of each metal in the bonded strip can be accommodated. In the bimetallic thermostat, this is used as a switch in control applications. If the magnitude of bending is measured, the bimetallic device becomes a thermometer. For such purposes, the strip is often arranged in a spiral or helical configuration, as shown in Figure 14.15b, as this gives a relatively large displacement of the free end for any given temperature change. The measurement sensitivity is increased further by choosing the pair of materials carefully such that the degree of bending is maximized, with Invar (a nickel-steel alloy) or brass being used commonly.

The system used to measure the displacement of the strip must be designed carefully. Very little resistance must be offered to the end of the strip, as otherwise the spiral or helix will distort and cause a false reading in measurement of the displacement. The device is normally just used as a temperature indicator, where the end of the strip is made to turn a pointer that moves against a calibrated scale. However, some versions produce an electrical output, using either a linear variable differential transformer or a fiber-optic shutter sensor to transduce the output displacement.

Bimetallic thermometers are used to measure temperatures between -75 and +1500 C. The inaccuracy of the best instruments can be as low as $\pm 0.5\%$ but such devices are quite expensive. Many instrument applications do not require this degree of accuracy in temperature measurements, and in such cases much less expensive bimetallic thermometers with substantially inferior accuracy specifications are used.

All such devices are liable to suffer changes in characteristics due to contamination of the metal components exposed to the operating environment. Further changes are to be expected arising from mechanical damage during use, particularly if they are mishandled or dropped. As the magnitude of these effects varies with their application, the required calibration interval must be determined by practical experimentation.

Pressure Thermometers

Pressure thermometers have now been superseded by other alternatives in most applications, still remain useful in a few applications such as furnace temperature measurement level of fumes prevents the use of optical or radiation pyrometers. Examples can also like found of their use as temperature sensors in pneumatic control systems. The ensing element in a pressure thermometer consists of a stainless-steel bulb containing a gas. If the fluid were not constrained, temperature rises would cause its volume However, because it is constrained in a bulb and cannot expand, its pressure rises i As the pressure thermometer does not strictly belong to the thermal expansion instruments but is included because of the relationship between volume and pressure to Boyle's law: PV = KT. The change in pressure of the fluid is measured by a rable pressure transducer, such as the Bourdon tube (see Chapter 15). This transducer lemented remotely from the bulb and is connected to it by a capillary tube as shown in 14.15c.

Pressure thermometers can be used to measure temperatures in the range between -250 and $+2000^{\circ}$ C, and their typical inaccuracy is $\pm 0.5\%$ of full-scale reading. However, the instrument resource has a particularly long time constant.

The most to protect the pressure-measuring instrument from the environment where the temperature is being measured can require the use of capillary tubes up to 5 m long, and the temperature gradient, and hence pressure gradient, along the tube acts as a modifying input that can infraduce a significant measurement error. Errors also occur in the short term due to mechanical damage and in the longer term due to small volumetric changes in the glass components. The rate of increase in these errors is mainly use related and therefore the required calibration interval must be determined by practical experimentation.

14.8 Quartz Thermometers

The quartz thermometer makes use of the principle that the resonant frequency of a material such as quartz is a function of temperature, and thus enables temperature changes to be translated into frequency changes. The temperature-sensing element consists of a quartz injust inclosed within a probe (sheath). The probe usually consists of a stanless steel which makes the device physically larger than devices such as thermocouples and the thermometers. The crystal is connected electrically so as to form the resonant element electronic oscillator. Measurement of the oscillator trequency therefore allows the temperature to be calculated.

Example that a very linear output characteristic over the temperature range between -4030°C, with a typical inaccuracy of $\pm 0.1\%$. Measurement resolution is typically 0.1°C

but versions can be obtained with resolutions as small as 0.0003°C. The characteristics of the instrument are generally very stable over long periods of time and therefore only infreque calibration is necessary. The frequency change form of output means that the device is insensitive to noise. However, it is very expensive and only available from a small number of manufacturers.

14.9 Fiber-Optic Temperature Sensors

Fiber-optic cables can be used as either intrinsic or extrinsic temperature sensors, as discusse in Chapter 13, although special attention has to be paid to providing a suitable protective coating when high temperatures are measured. Cost varies from \$1000 to \$5000, according to type, and the normal temperature range covered is 250 to 3000°C, although special devis can detect down to 100°C and others can detect up to 3600°C. Their main application it measuring temperatures in hard-to-reach locations, although they are also used when very high measurement accuracy is required. Some laboratory versions have an inaccuracy as low as $\pm 0.01\%$, which is better than a type S thermocouple, although versions used in infinite have a more typical inaccuracy of $\pm 1.0\%$.

While it is often assumed that fiber-optic sensors are intrinsically safe, it has been shown (Johnson, 1994) that fiammable gas may be ignited by the optical power levels available from some laser diodes. Thus, the power level used with optical fibers must be chosen carefully, and certification of intrinsic safety is necessary if such sensors are to be used in hazardous environments.

One type of intrinsic sensor uses cable where the core and cladding have similar refractive indices but different temperature coefficients. Temperature rises cause the refractive indices to become even closer together and losses from the core to increase, thus reducing the quantity of light transmitted. Other types of intrinsic temperature sensors include the cross-talk senses, phase-modulating sensor, and optical resonator, as described in Chapter 13. Research interactive indices to distributed temperature sensing using fiber-optic cable has also been reported. This can be used to measure things such as the temperature distribution along an cleaner supply cable. It works by measuring the reflection characteristics of light transmitted down a fiber-optic cable bonded to the electrical cable. By analyzing back-scattered radiation, a table of temperature versus distance along the cable can be produced, with a measurem inaccuracy of only $\pm 0.5^{\circ}$ C.

A common form of extrinsic sensor uses fiber-optic cables to transmit light from a remain targeting lens into a standard radiation pyrometer. This technique can be used with all of radiation pyrometers, including the two-color version, and a particular advantage is that this method of measurement is intrinsically safe. However, it is not possible to measure very low temperatures because the very small radiation levels that exist at low temperatures 600 mm in length. At temperatures exceeding 1000°C, lengths of fiber up to 20 m long can be used a light rule.

The entrem by accurate device that uses this technique is known as the Accufibre sensor. This is a form of relation pyrometer that has a black box cavity at the focal point of the lens system. A there optic cable is used to transmit radiation from the black box cavity to a spectrometric A there optic cable is used to transmit radiation from the black box cavity to a spectrometric A more that computes the temperature. This has a measurement range of 500 to 2000°C, a structure of 10^{-50} C, and an inaccuracy of only ±0.0025% of full scale.

the types of devices marketed as extrinsic fiber-optic temperature sensors consist of a content temperature sensor (e.g., a resistance thermometer) connected to a fiber-optic the no that transmission of the signal from the measurement point is free of noise. Such vices must include an electricity supply for the electronic circuit needed to convert the sensor supply into light variations in the cable. Thus, low-voltage power cables must be routed with the fiber-optic cable, and the device is therefore not intrinsically safe.

14.10 Color Indicators

The color of various substances and objects changes as a function of temperature. One use of this is in the optical pyrometer as discussed earlier. The other main use of color change is in special color indicators that are widely used in industry to determine whether objects placed in furnaces have reached the required temperature. Such color indicators consist of special paints or empose that are applied to an object before it is placed in a furnace. The color-sensitive component within these is some form of metal salt (usually of chromium, cobalt, or nickel). At a certain imperature, a chemical reaction takes place and a permanent color change occurs in the paint or crayon, although this change does not occur instantaneously but only happens over a period of time.

Hence, the molor change mechanism is complicated by the fact that the time of exposure as well as the temperature is important. Such crayons or paints usually have a dual rating that specifies the temperature and length of exposure time required for the color change to occur. If the imperature fises above the rated temperature, then the color change will occur in less than the effective ended to be a subset of the rate of temperature rise is slow with specified exposure time required for color change to occur. However, if the of temperature is high, the object will be significantly above the rated change uture of the paint/crayon by the time that the color change happens. In addition to the object in the furnace longer than necessary, this can also cause difficulty it excess temperature can affect the required metallurgical properties of the heated of

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Paints and crayons are available to indicate temperatures between 50 and 1250°C. A type exposure time rating is 30 minutes, that is, the color change will occur if the paint/crayon is exposed to the rated temperature for this length of time. They have the advantage of low typically a few dollars per application. However, they adhere strongly to the heated object, which can cause difficulty if they have to be cleaned off the object later.

Some liquid crystals also change color at a certain temperature. According to the design of sensors using such liquid crystals, the color change can either occur gradually during a temperature rise of perhaps 50°C or change abruptly at some specified temperature. The latter kinds of sensors are able to resolve temperature changes as small as 0.1°C and, according to type, are used over the temperature range from -20 to +100°C.

14.11 Change of State of Materials

Temperature-indicating devices known as Seger cones or pyrometric cones are used common in the ceramics industry. They consist of a fused oxide and glass material that is formed into a cone shape. The tip of the cone softens and bends over when a particular temperature is reached. Cones are available that indicate temperatures over the range from 600 to $\pm 2000^\circ$

14.12 Intelligent Temperature-Measuring Instruments

Intelligent temperature transmitters have now been introduced into the catalogues of aliminal instrument manufacturers, and they bring about the usual benefits associated with intelligent instruments. Such transmitters are separate boxes designed for use with transducers that have either a d.c. voltage output in the millivolt range or an output in the form of a resistance change. They are therefore suitable for use in conjunction with thermocouples, thermopheresistance thermometers, thermistors, and broad-band radiation pyrometers. Transmitters formula have nonvolatile memories where all constants used in correcting output values for modifying inputs, etc., are stored, thus enabling the instrument to survive power failures without losing such information. Other facilities in intelligent transmitters include adjustable damping, noise rejection, self-adjustment for zero and sensitivity drifts, and expanded measurement tange. These features allow an inaccuracy level of $\pm 0.05\%$ of full scale to be specified.

Mention must be made particularly of intelligent pyrometers, as some versions of these are able to measure the emissivity of the target body and automatically provide an emissivity correct output. This particular development provides an alternative to the two-color pyrometer when emissivity measurement and calibration for other types of pyrometers pose difficulty.

Digital thermometers (see Section 14.2.7) also exist in intelligent versions, where inclusion of a microprocessor allows a number of alternative thermocouples and resistance thermometers in be offered as options for the primary sensor.

of intelligent temperature transducers is significantly more than their nonintelligent contemport. and justification purely on the grounds of their superior accuracy is hard to Hencer, their expanded measurement range means immediate savings are made in terms of the reduction in the number of spare instruments needed to cover a number of measurement ranges. Their capability for self-diagnosis and self-adjustment means that they require attention much less frequently, giving additional savings in maintenance costs transmitters are also largely self-calibrating in respect of their signal processing clion. Although appropriate calibration routines still have to be applied to each sensor that the transmitter is connected to.

14.13 Choice between Temperature Transducers

The suitability of different instruments in any particular measurement situation depends substantially on whether the medium to be measured is a solid or a fluid. For measuring the name of solids, it is essential that good contact is made between the body and the transducer unless a radiation thermometer is used. This restricts the range of suitable transducers to the mouples, thermopiles, resistance thermometers, thermistors, semiconductor devices, and color indicators. However, fluid temperatures can be measured by any of the instruments described in this chapter, with the exception of radiation thermometers.

The most commonly used device in industry for temperature measurement is the base metal thermocouple. This is relatively inexpensive, with prices varying widely from a few dollars upward according to the thermocouple type and sheath material used. Typical inaccording is $\pm 0.5\%$ of full scale over the temperature range of -250 to $+1200^{\circ}$ C. Noble metal harmocouples are much more expensive, but are chemically inert and can measure temperatures up to 2300°C with an inaccuracy of $\pm 0.2\%$ of full scale. However, all types of thermocouples have a low-level output voltage, making them prone to noise and therefore unsuitable for measuring small temperature differences.

Resistance thermometers are also in common use within the temperature range of -270 to -0.50 °C, with a measurement inaccuracy of $\pm 0.5\%$. While they have a smaller temperature tange to an thermocouples, they are more stable and can measure small temperature differences. The platinum resistance thermometer is generally regarded as offering the best ratio of price to performance for measurement in the temperature range of -200 to +500 °C, with prices target form \$20.

with a typical cost of around \$5. They give a fast output response to temperature changes, with pool measurement sensitivity, but their measurement range is quite limited.

in the second accuracy. Thus, they are a viable alternative to these in many applications.

Integrated circuit transistor sensors are particularly inexpensive (from \$10 each), although their accuracy is relatively poor and they have a very limited measurement range (-50 tr) +150°C). Diode sensors are much more accurate and have a wider temperature range (-270 to) +200°C), although they are also more expensive (typical costs are anywhere from \$50 to \$R(t))

A major virtue of radiation thermometers is their noncontact, noninvasive mode of measurement. Costs vary from \$300 up to \$5000 according to type. Although calibration for the emissivity of the measured object often poses difficulties, some instruments nonprovide automatic calibration. Optical pyrometers are used to monitor temperatures above 600°C in industrial furnaces, etc., but their inaccuracy is typically $\pm 5\%$. Various forms of radiation pyrometers are used over the temperature range between -20 and +1800°C and can give measurement inaccuracies as low as $\pm 0.05\%$. One particular merit of narrow-band radiation pyrometers is their ability to measure fast temperature transients of duration as small as 10 µs. No other instrument can measure transients anywhere near as fast as this.

The range of instruments working on the thermal expansion principle are used mainly as temperature-indicating devices rather than as components within automatic control schemes. Temperature ranges and costs are: mercury-in-glass thermometers up to +1000°C (cost from a few dollars), bimetallic thermometers up to +1500°C (cost \$50 to \$150), and pressure thermometers up to +2000°C (cost \$100 to \$800). The usual measurement inaccuracy is in the range of ± 0.5 to $\pm 1.0\%$. The bimetallic thermometer is more rugged than liquid-in-glass types but less accurate (however, the greater inherent accuracy of liquid-in-glass types can only be realized if the liquid meniscus level is read carefully).

Fiber-optic devices are more expensive than most other forms of temperature sensors (confine up to \$6000) but provide a means of measuring temperature in very inaccessible locations. Inaccuracy varies from $\pm 1\%$ down to $\pm 0.01\%$ in some laboratory versions. Measurement range also varies with type, but up to $\pm 3600^\circ$ C is possible.

The quartz thermometer provides very high resolution $(0.0003^{\circ}C)$ is possible with special versions) but is expensive because of the complex electronics required to analyze the frequency-change form of output. It only operates over the limited temperature range of -40 to $+230^{\circ}C$, but gives a low measurement inaccuracy of $\pm 0.1\%$ within this range. It is not used commonly because of its high cost.

Color indicators are used widely to determine when objects in furnaces have reached the required temperature. These indicators work well if the rate of rise of temperature of the object in the furnace is relatively slow but, because temperature indicators only change color over a period of time, the object will be above the required temperature by the time that the indicator responds if the rate of rise of temperature is large. Cost is low; for example, a crayon typically costs \$5.

14.14 Calibration of Temperature Transducers

The find anestal difficulty in establishing an absolute standard for temperature has already been mentioned in the introduction to this chapter. This difficulty is that there is no practical way in such a conventent relationship can be established that relates the temperature of a body to assurable quantity expressible in primary standard units. Instead, it is necessary to use of reference calibration points for temperatures that are very well defined. These we been determined by research and international discussion and are published as the *Practical Temperature Scale*. They provide fixed, reproducible reference points for ture in the form of freezing points and triple points of substances where the transition to the full accussion states is sharply defined. The full set of defined points is:

Triple point of hydrogen	-259.3467°C
Triple point of neon	-248 5939°C
Triple point of oxygen	-218.7916°C
Triple point of argon	-189.3442 C
Triple point of mercury	-38.8344°C
Triple point of water	+0.0100°C
Melting point of gallium	+29.7646°C
Freezing point of indium	+156.5985°C
Freezing point of tin	+231.928°C
Freezing point of zinc	+419.527°C
Freezing point of aluminum	+660.323°C
Freezing point of silver	+961.78°C
Freezing point of gold	+1064.18°C
Freezing point of copper	+1084.62°C

For calibrating intermediate temperatures, interpolation between fixed points is carried out by use of the following reference instruments:

a helium gas thermometer for temperatures below 24.6°K

a platinum resistance thermometer for temperatures between 13.8°K and 961.8°C

a narrow band radiation thermometer for temperatures above +961.8°C

triple point method of defining fixed points involves use of a triple point cell. The cell of a sealed cylindrical glass tube filled with a highly pure version of the reference (e.g., mercury). This must be at least 99.9999% pure (such that contamination is less

The triple point of a substatute is the temperature and pressure at which the solid, liquid, and gas phases of that subcoextst in illumitedynamic equilibrium. For example, in the case of water, the single combination of and temperature at which solid ice, liquid water, and water vapor coexist in a stable equilibrium is a 611.73 millibars and a temperature of 273.16°K (0.01°C).

than one part in one million). The cell has a well that allows insertion of the thermometer being calibrated. It also has a valve that allows the cell to be evacuated down to the required triple point pressure.

The freezing point method of defining fixed points involves use of an ingot of the reference metal (e.g., tin) that is better than 99.99% pure. This is protected against oxidation inside a graphite crucible with a close-fitting lid. It is heated beyond its melting point and allowed to cool. If its temperature is monitored, an arrest period is observed in its cooling curve at the freezing point of the metal. The melting point method is similar but involves heating the material until it melts (this is only used for materials such as gallium where the melting point is defined more clearly than the freezing point). Electric resistance furnaces are available to carry out these procedures. Up to 1100°C, a measurement uncertainty of less than $\pm 0.5^{\circ}$ C is achievable.

The accuracy of temperature calibration procedures is fundamentally dependent on how accurately points on the IPTS can be reproduced. The present limits are:

1°K 0.3%	800 K 0.001%
10°K 0.1%	1500°K 0.02%
100°K 0.005%	4000° K 0.2%
273.15°K 0.0001%	10.000 K 6.7%

14.14.1 Reference Instruments and Special Calibration Equipment

The primary reference standard instrument for calibration at the top of the calibration chain is a helium gas thermometer, a platinum resistance thermometer, or a narrow-band radiation thermometer according to the temperature range of the instrument being calibrated, as explain at the end of the last section. However, at lower levels within the calibration chain, almost any instrument from the list of instrument classes given in Section 14.1 may be used for work calibration duties in particular circumstances. Where involved in such duties, of course, the instrument used would be one of high accuracy that was reserved solely for calibration duties. The list of instruments suitable for workplace-level calibration therefore includes mercury in glass thermometers, base metal thermocouples (type K), noble metal thermocouples (types B, R, and S), platinum resistance thermometers, and radiation pyrometers. However, a subset of this is commonly preferred for most calibration operations. Up to 950°C, the platinum resistance thermometer is often used as a reference standard. Above that temperature, up to about 1750°C, a type S (platinum/rhodium-platinum) thermocouple is usually employed. Type is (chromel-alumel) thermocouples are also used as an alternative reference standard for temperature calibration up to 1000°C.

Although no special types of instruments are needed for temperature calibration, the responsible of the environment within which one instrument is compared with another has to be controlled This requires purpose-designed equipment, which is available commercially from a bee of manufacturers.

Fire entirements of all temperature transducers other than radiation thermometers above a strature of 20°C, a furnace consisting of an electrically heated ceramic tube is commonly. The temperature of such a furnace can typically be controlled within limits of $\pm 2^{\circ}$ C over the range from 20 to 1600°C.

20°C, a stirred water buth is used to provide a constant reference temperature, and the emperaturement can, in fact, be used for temperatures up to 100°C. Similar stirred liquid buths using oil or salts (potentium/sodium nimite mixtures) can be used to provide reference interatures up to 600°C.

For the calibration of radiation thermometers, a radiation source, which approximates as cloudy as passible to the behavior of a black body, is required. The actual value of the emissivity of the marce must be measured by a surface pyrometer. Some form of optical beach is also imported to that instruments being calibrated can be held firmly and aligned accurately.

The simplest form of radiation source is a hot plate heated by an electrical element. The sequence of such devices can be controlled within limits of $\pm 1^{\circ}$ C over the range from 0 to CSC Land the typical eminivity of the plate surface is 0.85. Type R noble metal thermocouples and the plate are normally used as the reference instrument.

A black body cavity provides a heat source with a much better emissivity. This can be presented in various alternative forms according to the temperature range of the radiation increases to be calibrated, although a common feature is a blackened conical cavity with a own angle of about 15°.

For calibrating low-temperature radiation pyrometers (measuring temperatures in the range of 20 to 200°C), the black body cavity is maintained at a constant temperature (±0.5°C) by immersing it in a liquid bath. The typical emissivity of a cavity heated in this way is 0.995. Water is suitable for the bath in the temperature range of 20-90°C, and a efficient fluid is suitable for the range of 20-200°C. Within these temperature ranges, a mercury m-glass thermometer is used commonly as the standard reference calibration is although a platinum resistance thermometer is used when better accuracy is the standard reference calibration.

form of black body cavity is one lined with a refractory material and heated by an element. This gives a typical emissivity of 0.998 and is used for calibrating radiation at higher temperatures. Within the range of 200-1200°C, temperatures can be within limits of ± 0.5 °C, and a type R thermocouple is generally used as the trument. At the higher range of 600-1600°C, temperatures can be convolted units of $\pm 1°$ C, and a type B thermocouple (30% rhodium-platinum/6%)

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rbodium-platinum) is normally used as the reference instrument. As an alternative to thermocouples, radiation thermometers can also be used as a standard within ±0.5°C over the temperature range from 400 to 1250°C.

To provide reference temperatures above 1600°C, a carbon cavity furnace is used. This consists of a graphite tube with a conical radiation cavity at its end. Temperatures up to 2600°C can be maintained with an accuracy of \pm 5°C. Narrow-band radiation thermometers are used as the reference standard instrument.

Again, the aforementioned equipment merely provides an environment in which radiation thermometers can be calibrated against some other reference standard instrument. To obtain an absolute reference standard of temperature, a fixed-point, black body furnace is used. This has a radiation cavity consisting of a conical-ended cylinder that contains a crucible of 99.999% pure metal. If the temperature of the metal is monitored as it is heated up at a constant rate, an arrest period is observed at the melting point of the metal where the temperature corresponding to the output reading of the monitoring instrument at that jastant, as defined exactly. Measurement uncertainty is of the order of $\pm 0.3^{\circ}$ C. The list of metals, and their melting points, was presented earlier at the beginning of Section 14.14,

In the calibration of indiation thermometers, knowledge of the emissivity of the hot plate or black body furnace used as the radiation source is essential. This is measured by special types of surface pyrometer. Such instruments contain a hemispherical, gold-plated surface that is supported on a telescopic arm that allows it to be put into contact with the hot surface. The radiation emitted from a small hole in the hemisphere is independent of the surface emissivity of the measured body and is equal to that which would be emitted by the body if its emissivity value was 100. This radiation is measured by a thermopile with its cold junction at a controlled temperature. A black hemisphere is also provided with the instrument, which can be inserted to cover the gold surface. This allows the instrument to measure the normal radiation emission from the hot body and so allows the surface emissivity to be calculated by comparing the two radiation measurements.

Within this list of special equipment, mention must also be made of standard tangsten strip taraps, which are used for providing constant known temperatures in the calibration of optical pyrometers. The various versions of these provide a range of standard temperatures between 800 and 2300 °C to an accuracy of $\pm 2^{\circ}$ °C.

14.14.2 Celculating Frequency of Celibraties Checks

The meaner in which the appropriate frequency for calibration checks is determined for the various temperature-measuring instruments available was discussed in the instrument sprice presented in Section 14.1. The simplest instruments from a calibration point of view are

Equilibrium glass thermometers. The only parameter able to change within these is the volume of the glass used in their construction. This only changes very slowly with time, and hence only infrequent (e.g., annual) calibration checks are required.

The sequired frequency for calibration of all other instruments is either (a) dependent on the type of operating environment and the degree of exposure to it or (b) use related. In some cases, both of these factors are relevant.

Besistance thermometers and thermistors are examples of instruments where the drift in duracteristics depends on the environment they are operated in and on the degree of protection they have from that environment. Devices such as gas thermometers and quartz thermometers affer characteristics drift, which is largely a function of how much they are used (or minused!). Though in the case of quartz thermometers, any drift is likely to be small and only infrequent calibration checks will be required. Any instruments not mentioned so far suffer characteristics drift due to both environmental and use-related factors. The list of such instruments includes bimetallic thermometers, thermocouples, thermopiles, and radiation thermometers, In the case of thermocouples and thermopiles, it must be remembered that euror in the required duracteristics is possible even when the instruments are new, as discussed in Section 14.1, and therefore their calibration must be checked before use.

As the factors responsible for characteristics drift vary from application to application, the required frequency of calibration checks can only be determined experimentally. The procedure for doing this is to start by checking the calibration of instruments used in new applications at very short intervals of time and then to progressively lengthen the interval between calibration checks until a significant deterioration in instrument characteristics is abserved. The required calibration interval is then defined as that time interval predicted to the before the characteristics of the instrument have drifted to the limits allowable in that particular measurement application.

Working and reference standard instruments and ancillary equipment must also be calibrated percentration. An interval of 2 years is usually recommended between such calibration checks, strongh monthly checks are advised for the black body cavity furnaces used to provide and the reference temperatures in pyrometer calibration. Standard resistance thermometers and thermocouples may also used more frequent calibration checks if the conditions (especially of temperature) and frequency of use demand them.

14.14.3 Procedures for Calibration

The standard way of calibrating temporature transducers is to put them into a temperaturetemperature descent together with a standard matrument or to use a radiant heat marce of controlled temperature with high emissivity in the case of radiation thermometers. In either the controlled temperature must be measured by a standard instrument whose calibration

is traceable to reference standards. This is a suitable method for most instruments in the calibration chain but is not necessarily appropriate or even possible for process instruments at the lower end of the chain.

In the case of many process instruments, their location and mode of fixing make it difficult or nometimes impossible to remove them to a laboratory for calibration checks to be carried out. In this event, it is standard practice to calibrate them in their normal operational position using a reference instrument that is able to withstand whatever hostile environment may be present. If this practice is followed, it is imperative that the working standard instrument is checked regularly to ensure that it has not been contaminated.

Such as situ calibration may also be required where process instruments have characteristics, that are sensitive to the environment in which they work so that they are calibrated under their usual operating conditions and are therefore accurate in normal use. However, the preferred way of dealing with this situation is to calibrate them in a laboratory with ambient conditions (of pressure, hamidity, etc.) set up to mirror those of the normal operating environment. This alternative avoids having to subject reference calibration instruments to harsh chemical environments that are commonly associated with manufacturing processes.

For instruments at the lower end of the calibration chain, that is, those measuring process variables, it is common practice to calibrate them against an instrument that is of the same type but of higher accuracy and reserved only for calibration duties. If a large number of different types of instruments have to be calibrated, however, this practice leads to the need to keep a large number of different calibration instruments. To avoid this, various reference instruments are available that can be used to calibrate all process instruments within a given temperature-measuring range. Examples are the liquid-in-glass thermometer (0 to $+200^{\circ}$ C), platinum resistance thermometer (-200 to $+1000^{\circ}$ C), and type S thermoeouple (+600 to $+1750^{\circ}$ C). The optical pyrometer is also often used as a reference instrument at this level for the calibration of other types of radiation thermometers.

For calibrating instruments further up the calibration chain, particular care is needed with regard to both the instruments used and the conditions they are used under. It is difficult and expensive to meet these conditions and hence this function is subcontracted by most companies to specialist laboratories. The reference instruments used are the platinum resistance thermometer in the temperature range of -200 to $+1000^{\circ}$ C, the platinum-platinum/10% shodium (type S) thermocouple in the temperature range of +1000 to $+1750^{\circ}$ C, and a narrow-band radiation thermometer at higher temperatures. An exception is *optical pyrometers*, which are calibrated as explained in the final paragraph of this chapter. A particular note of causion must be made where platinum-rhodium thermocouples are used as a standard. These are very puose to contamination, and if they need to be handled at all, this should be done with very clean hands. netwo ending this chapter, it is appropriate to mention one or two special points that concern are calibration of thermocouples. The mode of construction of thermocouples means that the characteristics can be incorrect even when they are new, due to faults in either the tempercity of the thermocouple materials or the construction of the device. Therefore, alibration checks should be carried out on all new thermocouples before they are put into use. The procedure for this is to immerse both junctions of the thermocouple in an ice bath and the state output with a high-accuracy digital voltmeter (±5 pV). Any output greater than suV would indicate a fault in the thermocouple material and/or its construction. After this check thermocouples when they are brand new, the subsequent rate of change of thermoelectric beracteristics with time is entirely dependent on the operating environment and the degree exposure to it. Particularly relevant factors in the environment are the type and concentration of trace metal elements and the temperature (the rate of contamination of thermocouple materials with trace elements of metals is a function of temperature). A suitable calibration featurency can therefore only be defined by practical experimentation, and this must be reviewed whenever the operating environment and conditions of use change. A final word of mution when calibrating thermocouples is to ensure that any source of electrical or magnetic fields is excluded, as these will induce erromeous voltages in the sensor.

Expectal comments are also relevant regarding calibration of a radiation thermometer. As well as normal accuracy checks, its long-term stability must also be verified by leating its output over a period that is 1 hour longer than the manufacturer's specified "warm-up" time. This shows up any in components within the instrument that are suffering from temperature-induced intracteristics drift. It is also necessary to calibrate radiation thermometers according to the constance characteristic of the body whose temperature is being measured and according to the level of energy losses in the radiation path between the body and measuring instrument. Each emissivity calibration must be carried out for every separate application that the informent is used for, using a surface pyrometer.

Finally, it should be noted that the usual calibration procedure for *optical pyrometers* is to sight them on the filament of a tungsten strip lamp in which the current is measured accurately. This method of calibration can be used at temperatures up to 2500° C. Alternatively, they can be calibrated against a standard radiation pyrometer.

14.15 Summary

Our review at the start of the chapter revealed that there are 10 different physical principles used minimum as the basis for temperature-meaning devices. During the course of the chapter, we included at how each of these principles is exploited in various classes of temperatureting devices.

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We stand off by looking at the thermoelectric effect and its use in themmecouples and thermopiles, and also the derived devices of digital thermometers and continuous thermocouples. Thermocouples are the most commonly used devices for industrial applications of temperature measurement. However, despite their relatively simple operating concept of generating in output voltage as a function of the temperature they are exposed to, proper use of thermocouples requires, an understanding of two thermoelectric laws. These laws were presented and their application was explained by several examples. We also saw how the output of a thermocouple has to be interpreted by thermocouple tables. We went on to look at the different types of thermocouples, available, which range from a number of inexpensive, base metal types to expensive ones based on noble metals. We looked at the typical characteristics of these and discussed typical applications. Moving on, we noted that thermocouples are quite deficate devices that can suffer from both mechanical damage and chemical damage in certain operating environments, and we discussed ways of avoiding such problems. We also looked briefly at how thermocouples are rande.

Our next subject of study concerned resistance thermometers and thermistors, both of these being devices that convert a change in temperature into a change in the resistance of the device. We noted that both of these are also very commonly used measuring devices. We looked at the theoretical principles of each of these and discussed the range of materials used in each class of device. We also looked at the typical device characteristics for each construction material.

Next, we looked at assiconductor devices in the form of diodes and transistors and discussed their characteristics and mode of operation. This discussion revealed that although these devices are less expensive and more linear than both thermocouples and resistance thermometers, their typical measurement range is relatively low. This limits their applicability and means that they are not used as widely as they would be if their measurement range was greater.

Moving on, we looked at the class of devices known as radiation thermometers (alternatively known as radiation pyrometers), which exploit the physical principle that the peak wavelength of radiated energy emission from a body varies with temperature. The instrument is used by pointing it at the body to be measured and analyzing the radiation emitted from the body. This has the advantage of being a noncontact mode of temperature measurement, which is highly attractive in the food and drug industries and any other application where contaminative of the measured quantity has to be avoided. We also observed that different versions of radiation thermometers are capable of measuring temperatures between -100 and +10,000 C, with measurement inaccuracy as low as $\pm 0.05\%$ in the more expansive versions. Despite these obvious merits, careful calibration of the instrument to the type of body being measured in essential, as the characteristics of radiation thermometers are critically dependent on the emismivity of the measured body, which varies widely between different materials.

This stage in the chapter unaked the and of discussion of the four most commonly used types of temperature-measuring devices. The remaining techniques all have niche applications but none are "large volume" uses. The first one covered of these "other techniques" was such. Also known as thermal imaging, this involves scanning an infrared radiation across either a single object or a scene containing several objects. The information efficiency is then processed and an output in the form of the temperature distribution across object is produced. It has differs from other forms of temperature sensors in providing constition on temperature distribution across an object or scene rather than the temperature at these discrete point. Temperature measurement over the range from -20 C up to +1500°C in possible.

Cur next subject of study concerned the liquid-in-glass thermometer, bimetallic thermometer, and pressure thermometer. These are all usually classed as thermal expansion-based devices, abbough this is not strictly true in the case of the last one, which is based on the change in pressure of a fluid inside a fixed-volume stainless-steel bulb. The characteristics and typical applications of each of these were discussed.

The quartz thermometer then formed the next subject of study. This uses the principle that the maximum frequency of a material such as quartz changes with temperature. Such devices have very high specifications in terms of linearity, long life, accuracy, and measurement resolution. Unfortunately, their relatively high cost severely limits their application.

Maxing on, we then looked at fiber-optic temperature sensors. We saw that their main application is measuring temperatures in hard-to-reach locations, although they are also used when very high measurement accuracy is required.

Next, we discussed color indicators. These consist mainly of special paints or crayons that charge color at a cartain temperature. They are used primarily to determine when the temperature of objects placed in a furnace reach a given temperature. They are relatively temperature, and different paints and crayons are available to indicate temperatures between 50 and 1250°C. In addition, certain liquid crystals that change color at a certain temperature are also used as color indicators. These have better measurement resolution than paints and crayons and, while some versions can indicate low temperatures down to -20° C, the highest importance that they can indicate is $+100^{\circ}$ C.

foodly, our discussion of the application of different physical principles in temperature measurement brought us to Seger cones. Also known as pyrometric cones, these have a conical where the tip melts and bends over at a particular temperature. They are used commonly is the ceramics industry to detect a given temperature is reached in a furnace.

The design of the continued with a look at intelligent measuring devices. These are designed to with various actnows such as thermocouples, thermopiles, resistance thermometers, and broad band cadiation pyrameters. Intelligence within the device gives them such as adjustable damping, noise rejection, self-adjustment for zero and sensitivity was, self-fault diagnosis, self-calibration, reduced maintenance requirement, and an expanded

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measurement range. These features reduce typical measurement inaccuracy down to ± 0.05 m of full scale.

This completion of the discussion on all types of intelligent and nonintelligent devices allowed us to go on to consider the mechanisms by which a temperature-measuring device is chosen lag a particular application. We reviewed the characteristics of each type of device in turn and looked at the sorts of circumstances in which each might be used.

Our final subject of study in the chapter was that of calibrating temperature-measuring devices. We noted first of all that a fundamental difficulty exists in establishing an absolute standard for temperature and that, in the absence of such a standard, fixed reference points for temperature were defined in the form of freezing points and triple points of certain substances. We then were on to look at the calibration instruments and equipment used in workplace calibration. We also established some guidelines about how the frequency of calibration should be set. Finally, we looked in more detail at the appropriate practical procedures for calibrating various types of ansors.

14.16 Problems

- 14.1. Discuss briefly the different physical principles used in temperature-measuring instruments and give examples of instruments that use each of these principles.
- 14.2. (a) How are thermocouples manufactured? (b) What are the main differences between base metal and noble metal thermocouples? (c) Give six examples of the materials used to make base metal and noble metal thermocouples. (d) Specify the international code letter used to designate thermocouples made from each pair of materials that you give in your answer to part (c).
- 14.3. Explain what each of the following are in relation to thermocouples: (a) extension leads, (b) compensating leads, (c) law of intermediate metals, and (d) law of intermediate temperature.
- 14.4. What type of base metal thermocouple would you recommend for each of the following applications?
 - (a) measurement of subzero temperatures
 - (b) measurement in oxidizing atmospheres
 - (c) measurement in reducing atmospheres
 - (d) where high sensitivity measurement is required
- 14.5. Why do thermocouples need protection from some operating environments and how in this protection given? Discuss any differences between base metal and noble metal thermocouples in the need for protection.
- 14.6. The temperature of a fluid is measured by immersing an iron-constantan thermocouple in it. The reference junction of the thermocouple is maintained at 0°C in an irce

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both and an output e.m.f. of 5.812 mV is measured. What is the indicated fluid temperature?

- 14.7. The temperature of a fluid is measured by immensing a type K thermocouple in it. The reference junction of the thermocomple is resintained at 0°C in an ice bath and an output e.m.f. of 6.435 mV is measured. What is the indicated fluid temperature? The output s.m.f. from a chromel-nlurnel thermocouple (type K), with its reference
- innction maintained at 0°C, is 12.207 mV. What is the measured temperature? 14.9. The output can.f. from a nicrosil-mult thermocouple (type N), with its reference
- innction maintained at 0°C, is 4.21 mV. What is the measured temperature?
- 14.10. The output cum.f. from a chromel-constantan thermocouple whose hot junction is immersed in a fluid is measured as 18.25 mV. The reference junction of the thermocouple is maintained at 0°C. What is the temperature of the fluid?
- 14.11. A copper-constantan thermocouple is connected to copper-constantan estonsion wires and the reference junction is exposed to a room temperature of 20 C. If the output voltage measured is 6.537 mV, what is the indicated temperature at the hat junction of the thermocouple?
- 14.12. A platinum/10% thodium-platinum (type S) thermocouple is used to measure the temperature of a furnace. Output e.m.f., with the reference junction maintained at 50°C, is 5.975 mV. What is the temperature of the furnace?
- 14.13. In a particular industrial situation, a accrosil-null thermocouple with necrosil-null extension wares is used to measure the temperature of a fluid. In connecting up this measurement system, the instrumentation engineer responsible has inadvertently interchanged the extension wires from the thermocouple. The ends of the extension wires are held at a reference temperature of 0 C and the output e.m.f. measured is 21.0 mV. If the junction between the thermocouple and extension wires is at a temperature of 50°C, what temperature of fluid is indicated and what is the true fluid temperature?
- 14.14. A copper-constantan thermocouple measuring the temperature of a hot fluid is connected by mintake with chromel-constantan extension wires (such that the two constantan wires are connected together and the chromel extension wire is connected to the copper thermocouple wire). If the actual fluid temperature was 150°C, the junction between the thermocouple and extension wires was at 20°C, and the reference junction was at 0 C, calculate the e.m.f. measured at the open ends of the extension wires. What fluid temperature would be deduced from this measured e.m.f. (assuming that the error of using the wrong extension wires was not known)? (Hint: Apply the law of intermediate metals for the thermocouple-extension lead innction.)

14.15. This question is similar to the last one but involves a chroniel-constant in thermocouple wher than a copper-constantan one. In this case, an ongeneer installed a chromelconstantan thermocouple but used copper-constantan extension leads (such that the two constantas wares were connected together and the copper extension wire was

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connected to the chromel thermocouple wise). If the thermocouple was measuring a has fluid whose real temperature is 150°C, the junction between the thermocouple and the extension leads was at 80°C, and the reference junction was at 0°C:

(a) Calculate the e.m.f. (voltage) measured at the open cods of the extension water

- (b) What fluid temperature would be deduced from this measured e.m.f., assuming that the error is using the incorrect leads was not known?
- 14.16. While installing a chromel-constantan thermocouple to measure the temperature of a fluid, it is connected by mistake with copper-constantan extension leads (such that the two constantan wires are connected together and the copper extension wire is connected to the chromel thermocouple wire). If the fluid temperature was actually 250°C and the junction between the thermocouple and extension wires if the roference what e.m.f. would be measured at the open ends of the extension wires if the roference junction is montained at 0°C? What fluid temperature would be deduced from this (assuming that the connection mistake was not known)?
- 14.17. In connecting extension leads to a chromel-slumel thermocouple, which is measuring the temperature of a fluid, a technicism connects the leads the wrong way round (such that the chromel estension lead is connected to the alumel thermocouple lead and vice versal. The junction between the thermocouple and extension leads is at a temperature of 100°C and the reference junction is maintained at 0°C is as ice bath. The technicism measures an output e.m.f. of 12,212 mV at the open ends of the extension leads.
 - (a) What fluid temperature would be deduced from this measured e.m.f.?

(b) What is the true fluid temperature?

- 14.18. A chromel-comstantart thermocouple measuring the temperature of a fluid is connected by mistake with copper-constantan extension leads (such that the two constantan wire are connected together and the copper extension lead wire is connected to the thermocouple wire). If the fluid temperature was actually 250°C and the junction between the thermocouple and extension leads was at 90°C, what e.m.f. would be measured at the open ends of the extension leads if the reference junction is manual at 0°C? What fluid temperature would be deduced from this (assuming that the connection error was not known)?
- 14.19. Extension leads used to measure the output e.m.f. of an ison-constantan thermoccurs measuring the temperature of a fluid are connected the wrong way round by missure (such that the iron extension lead is connected to the constantan thermocouple with and vice vorm). The junction between the thermocouple and extension leads is at a temperature of 120°C and the reference junction is at a room temperature of 21°C. The output sumf, measured at the open ends of the extension leads is 27.390 mV.
 - (a) What fluid temperature would be deduced from this measured e.m.f. assuming that the mistake of connecting the extension leads the woong way round was not known about?
 - (b) What is the true fluid temperature?

The temperature of a bot fluid is measured with a copper-constantan thermocouple but, by mistake, this is connected to chromel-constant an extension wires (mach that the no constantan wares are connected together and the chromel extension wire is connected to the copper thermocouple wire). If the actual fluid temperature was 200 °C. the junction between the thermocouple and extension wires was at 50 C, and the reference junction was at 0°C, calculate the e.m.f. measured at the open ends of the extension wires. What fluid temperature would be deduced from this measured e.m.f. (assuming that the error of using the wrong extension wires was not known)?

In a particular industrial situation, a chromel-alumel thermocouple with chromelstume! extension wires is used to measure the temperature of a fluid. In connecting up his measurement system, the instrumentation engineer responsible has inadvertantly interchanged the extension wires from the thermocouple (such that the chromel thermocouple wire is connected to the alumel extension least wire, etc.). The open ends of the extension leads are held at a reference temperature of 0 C and are connected to a voltmeter, which measures in e.m f. of 18.75 mV. If the junction between the thermocouple and extension wires is at a temperature of 38°C:

- (a) What temperature of fluid is indicated?
- (b) What is the true fluid temperature?
- 14.22. A copper-constantan thermocouple measuring the temperature of a hot fluid is connected by mintake with iron-constantan extension wires (such that the two constantan wises are connected together and the iron extension wire is connected to the copper thermocouple wire). If the actual fluid temperature was 200°C, the junction between the thermocouple and extension wires was at 160°C, and the reference function was at 0°C, calculate the e.m.f. measured at the open ends of the extension wires. What finid temperature would be deduced from this measured e.m.f. (assuming that the error of using the wrong extension wires was not known)?
- 14.23. in a particular industrial situation, a nicrosil-mult thermocouple with nicrosil-aisid extension wires is used to measure the temperature of a fluid, in connecting up this measurement system, the instrumentation engineer responsible has inadvertantly interchanged the entension wires from the thermocouple tsuch that the nicrosil dermocouple wire is connected to the nimil extension lend wire, etc.). The open ends af the extension leads are held at a reference temperature of 0°C and are connected to a noitmeter, which measures an e.m.f. of 17.51 mV. If the junction between the mermocouple and extension wires is at a temperature of 140°C:
 - (a) What temperature of fluid is indicated?
 - (b) What is the true fluid temperature?
- 14 24. Explain what the following met thermocouple, continuous thermocouple, thermopile, and digital theymometer. 14.75

.

When is the International Practical Temperature Scale? Why is it necessary in integerature sensor calibration and how as is used?

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14.26.	Resistance thermometers and thermistors are both temperature-measuring devices that
	convert the measured temperature into a resistance change. What are the main
	differences between these two types of devices in respect of the materials used in their
	constructions, their cost, and their operating characteristics?

- 14.27. Discuss the main types of radiation thermometers available. Now do they work and what are their main applications?
- 14.28. Name three kinds of temperature-measuring devices that work on the principle of thermal expansion. Explain how each works and what its typical characteristics are
- 14.29. Explain how fiber-optic cables can be used as temporature sensors.
- 14.30. Discuss the calibration of temperature sensors, mentioning what reference instruments are typically used.

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CHAPTER 15

Pressure Measurement

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15.1 Introduction

We are covering pressure measurement next in this chapter because it is required very commonly in most industrial process control systems and is the next-most measured process, parameter after temperature. We shall see that many different types of pressure-sensing and pressure measurement systems are available to satisfy this requirement. However, before considering these in detail, it is important for us to understand that pressure can be quantified in three alternative ways in terms of absolute pressure, gauge pressure, or differential pressure. The formal definitions of these are as follows.

Absolute pressure: This is the difference between the pressure of the fluid and the absolute zero of pressure.

Gauge pressure: This describes the difference between the pressure of a fluid and atmospheric pressure. Absolute and gauge pressures are therefore related by the expression:

Absolute pressure = Gauge pressure + Atmospheric pressure.

A typical value of atmospheric pressure is 1.013 bar. However, because atmospheric pressure varies with abitude as well as with weather conditions, it is not a fixed quantity. Therefore, because gauge pressure is related to atmospheric pressure, it also is not a fixed quantity.

Differential pressure: This term is used to describe the difference between two absolute pressure values, such as the pressures at two different points within the same fluid (often between the two sides of a flow restrictor in a system measuring volume flow rate).

Pressure is a quantity derived from the fundamental quantities of force and area and is usually measured in terms of the force acting on a known area. The SI unit of pressure is the Pascal, which can alternatively be expressed as Newtons per square meter. The bar, which is equal to 10,000 Pascal, is a related metric unit that is more suitable for measuring the most typically met pressure values. The unit of pounds per square inch is not an SI unit, but is still in widespread use, especially in the United State and Canada. Pressures are also nometimes expressed as inches of mercury or inches of water, particularly when measuring blood pressure or pressures in gas pipelines. Then two measurement units derive from the height of the liquid column in manometers, which were a very common method of pressure measurement in the past. The form is a further unit of measurement used particularly to express low prensures (1 torr = 133.3 Pascal).

To avoid ambiguity in pressure measurements, it is usual to append one or more letters in pressure: (a) or (abs) indicates absolute pressure, (g) indicates gauge pressure; and (d) specifies differential pressure. Thus, 2.57 bir (g) means that the pressure is 2.57 bir measured as gauge pressure. In the case of the pounds per square inch unit of pressure measurement, which is still in widespread use, it is usual to express absolute, gauge, and differential pressure as paia, pag.

Absolute pressure measurements are made for such purposes as aircraft altitude measurement (in instruments known as altimeters) and when quantifying atmospheric pressure. Very low pressures are also normally measured as absolute pressure values. Gauge pressure peasurements are made by instruments such as those measuring the pressure in vehicle tires and those measuring pressure at various points in industrial processes. Differential pressure is measured for some purposes in industrial processes, capecially as part of some fluid flow pressurements devices.

In most applications, typical values of pressure measured range from 1.013 bar (the mean accoupteric pressure) up to 7000 bar. This is considered to be the "normal" pressure range, and a large number of pressure sensors are available that can measure pressures in this range. Measurement requirements outside this range are much less common. While some of the pressure sensors developed for the "normal" range can also measure pressures that are either lower or higher than this, it is preferable to use special instruments that have been specially designed to satisfy such low- and high-pressure measurement requirements. In the case of low measures, such special instruments are commonly known as vacuum gauges.

Our discussion summarizes the main types of prossure sensors in use. This discussion is concerned primarily only with the measurement of static pressure, because the measurement of dynamic pressure is a very specialized area that is not of general interest. In general, dynamic pressure measurement requires special instruments, although modified versions of displaragen-type sensors can also be used if they contain a suitable displacement sensor (usually either a giezoelectric crystal or a capacitive element).

15.2 Diaphragms

The disphragm, shows achematically in Figure 15.1, is one of three types of elastic-element pressure transducers. Applied pressure causes displacement of the disphragm and this movement is measured by a displacement transducer. Different versions of disphragm and this movement both absolute pressure (up to 50 bar) and gauge pressure (up to 2000 bar) according to whether the space on one side of the disphragm is, respectively, evacuated or open to the atmosphere. A displaragm can also be used to measure differential pressure (up to 2.5 bar) by applying the two pressures to the two sides of the disphragm. The disphragm can be plastic, metal alloy, standers meet, or certaintic. Plastic disphragms are the least expensive, but metal disphragms give better mouracy. Stainless used is mornally used in high temperature or corrowine environments. Commic disphragms are to strong acids and alkalis and are used when the operating environment is particularly hawh. The name *anevoid gauge* is sometimes used to describe this type of gauge when the disphragm is metallic.



Schematic representation of a diaphragm pressure sensor

The typical magnitude of displacement displacement is 0.1 mm, which is well suited to a straingauge type of displacement-measuring transducer, although other forms of displacement measurements are also used in some kinds of displaragm-based sensors. If the displacement is measured with strain gauges, it is normal to use four strain gauge arranged in a bridge clacuit configuration. The output voltage from the bridge is a function of the resistance change due to the strain in the diaphragm. This arrangement automatically provides compensation for environmental temperature changes. Older pressure transducers of this type used metallic strain gauges bonded to a diaphragm typically made of stainless steel. However, apart from manufacturing difficulties arising from the problem of bonding the gauges, metallic strain gauges have a low gauge factor, which means that the low output from the strain gauge bridge has to be amplified by an expensive d.c. amplifier. The development of semiconductor (piezorenistive) strain gauges provided a solution to the low-output problem, as they have gauge factors up to 100 times greater than metallic gauges. However, the difficulty of bonding gauges to the diaphragm remained and a new problem emerged regarding the highly nonlinear characteristic of the strain-output relationship.

The problem of strain-gauge bonding was solved with the emergence of monolithic piezonesistive pressure transducers. These have a typical measurement uncertainty of $\pm 0.5\%$ and are now the most commonly used type of diaphragm pressure transducer. The monolithic cell consists of a diaphragm made of a minor sheet into which resistors are diffused during the manufacturing process. Such pressure transducers can be made very small and are often known as *nulcroarnswirk*. Also, in addition to avoiding the difficulty with bonding, such monolithic nilicon-measuring cells have the advantage of being very inexpensive to manufacture in large quantities. Although the inconvenience of a nonlinear characteristic remains, this is normally overcome by processing the output signal with an active linearization circuit or incorporating the cell into a microprocessor-based intelligent measuring transducer. The latter usually provide

subspine-to-digital conversion and interrupt facilities within a single chip and give a digital that is integrated readily into computer control schemes. Such instruments can also offer automatic temperature compensation, built-in diagnostics, and simple calibration produces. These features allow measurement inaccuracy to be reduced down to a value as low as $\pm 0.1\%$ of full-scale reading.

15.3 Capacitive Pressure Sensor

A capacitive pressure sensor is simply a disphragm-type device in which disphragm displacement is determined by measuring the capacitance change between the disphragm and a metal plate that is close to it. Such devices are in common use and are sometimes known as *Baratron gauges*. It is also possible to fabricate capacitive elements in a silicon chip and thus form very small *microsensors*. These have a typical measurement unconsisty of $\pm 0.2\%$.

15.4 Fiber-Optic Pressure Sensors

Fiber-optic sensors, also known as optical pressure sensors, provide an alternative method of measuring displacements in displycage and Boundon tube pressure sensors by optoelectronic means and enable the resulting sensors to have a lower mass and size compared with sensors in which displacement is measured by other methods. The shutter sensor described earlier in Chapter 13 is one form of fiber-optic displacement sensor. Another form is the fotonic sensor shown in Figure 15.2 in which light travels from a light source, down an optical fiber, reflected back from a displacement, and then travels hack along a second fiber to a photodetector. There is a characteristic relationship between the light reflected and the distance from the fiber ends to the displacement and hence the measured pressure.



Apart from the mass and size advantages of fiber-optic displacement sensors, the output signal is immune to electromagnetic noise. However, measurement accuracy is usually inferior to that provided by alternative displacement sensors, and the choice asch sensors also incurs a cost penalty. Thus, sensors using fiber optics to measure displacement tend to be limited to applications where their small size, low mass, and immunity to electromagnetic noise are particularly advantageous.

Apart from the limited use with diaphragm and Bourdon tube stansors, fiber-optic cables are also used in several other ways to measure pressure. A form of fiber-optic pressure sensur known as a *microbend sensor* is sketched in Figure 13.8a. In this, the refractive index of the fiber (and hence the intensity of light transmitted) varies according to the mechanical deformation of the fiber caused by pressure. The sensitivity of pressure measurement can be optimized by applying pressure via a roller chain such that bending is applied periodically (sen Figure 13.8b). The optimal pitch for the chain varies according to the radius, refractive index and type of cable involved. Microbend sensors are typically used to measure the small pressure changes generated in Vortex shedding flowmeters. When fiber-optic sensors are used in this flow measurement role, the alternative arrangement shows in Figure 15.3 can be used, where a fiber-optic cable is merely specified across the pipe. This often simplifies the detection of vortices.

Phase-modulating fiber-optic pressure sensors also exist. The mode of operation of these was discussed in Chapter 13.

15.5 Bellows

Bellows, illustrated achematically in Figure 15.4, are another elastic-element type of pressure sensor that operate on very similar principles to the diaphragm pressure sensor. Pressure changes within the bellows, which are typically fabricated as a seamless tube of either metal or metal alloy, produce translational motion of the end of the bellows that can be measured by capacitive, inductive (LVDT), or potentiometric transducers. Different versions can measure either absolute pressure (up to 2.5 bur) or gauge pressure (up to 150 bar). Double-bellows versions also exist that are designed to measure differential pressures of up to 30 bar.

Believes have a typical measurement uncertainty of only $\pm 0.5\%$, but have a relatively high manufacturing cost and are prove to failure. Their principle manibute in the past has been their greater measurement measitivity compared with disphragm sensors. However, advances in electronics mean that the high-sensitivity requirement can usually be satisfied now by disphragm-type devices, and usage of believes is therefore failing.



15.6 Bourdon Tube

The Bandon table is also an elastic element type of pressure transduces. It is relatively stative and is and commonly for measuring the gauge pressure of both generals and liquid from a complete of a specially shaped piece of oval-mection, flexible, metal table that is fixed at

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one end and free to move at the other end. When pressure is applied at the open, fixed end of the tube, the oval cross section becomes more circular. In consequence, there is displacement of the free end of the tube. This displacement is measured by some form of displacement transluctor, which is commonly a potentiometer or LVDT. Capacitive and optical rensors are also sometimes used to measure the displacement.

The three common shapes of Bourdon tubes are shown in Figure 15.5. The maximum possible deflection of the free end of the tube is proportional to the angle subtended by the arc through which the tube is bent. For a C-type tube, the maximum value for this arc is somewhat less than 360°. Where greater measurement sensitivity and resolution are required, spiral and helical tubes are used. These both give much greater deflection at the free end for a given applied pressure. However, this increased measurement performance is only gained at the expense of a substantial increase in manufacturing difficulty and cost compared with C-type tubes and is also associated with a large decrease in the maximum pressure that can be measured. Spiral and helical types are sometimes provided with a rotating pointer that moves against a scale to give a visual indication of the measured pressure.

C-type tubes are available for measuring pressures up to 6000 bar. A typical C-type tube of 25 mm radius has a maximum displacement travel of 4 mm, giving a moderate level of measurement resolution. Measurement inaccuracy is typically quoted at $\pm 1\%$ of full-scale



Three forms of a Bourdon tube.

effection. Similar accuracy is available from helical and spiral types, but while the measurement resolution is higher, the maximum pressure measurable is only 700 bar.

The existence of one potentially major source of error in Bourdon tube pressure measurement has not been widely documented, and few manufacturers of Bourdon tubes make any attempt to makes in their products appropriately. The problem is concerned with the relationship between the fluid being measured and the fluid used for calibration. The pointer of Bourdon tubes is normally set at zero during manufacture, using air as the calibration medium. However, if a different fluid, especially a liquid, is subsequently used with a Bourdon tube, the fluid in the tube will cause a nonzero deflection according to its weight compared with air, resulting in a reading error of up to 6%. This can be avoided by calibrating the Bourdon tube with the fluid in the measured instead of with air, assuming of course that the user is aware of the problem. Alternatively, correction can be made according to the calculated weight of the fluid in the tube. Infortunately, difficulties arise with both of these nolutions if air is trapped in the tube, as this will prevent the tube being filled completely by the fluid. Then, the amount of fluid actually in the tube, and its weight, will be unknown.

in conclusion, therefore, Bourdon tubes only have guaranteed accuracy limits when measuring paseous pressures. Their the for accurate measurement of liquid pressures poses great difficulty unless the gauge can be totally filled with liquid during both calibration and measurement, a condition that is very difficult to fulfill practically.

15.7 Manometers

Monometers are passive instruments that give a visual indication of pressure values. Various types exist.

15.7.1 U-Tube Memoryster

The U-tube manometer, shown in Figure 15.6a, is the most common form of manometer. Applied pressure causes a displacement of liquid inside the U-shaped glass tube, and output pressure reading P is made by observing the difference, h, between the level of liquid in the two halves of the tube A and B, according to the equation $P = h\rho_B$, where ρ is the specific gravity of the fluid. If an unknown pressure is applied to side A, and side B is open to the atmosphere, the compart reading is gauge pressure. Alternatively, if side B of the tube is sealed and evacuated, the output meading is absolute pressure. The U-tube manometer also measures the differential pressure ($p_1 - p_2$), according to the expression ($p_1 - p_2$) = $h\rho_B$, if two unknown pressures p_1 and p_2 are applied, respectively, to sides A and B of the tube.

Output readings from U-tube manometers are subject to error, principally because it is very difficult to judge startly where the meniacus levels of the liquid are in the two halves of the



Three forms of manometer: (a) U tube, (b) well type, and (c) indined type.

tabe. In absolute pressure measurement, an additional error occurs because it is impossible to totally evacuate the closed end of the tube.

U-tube manometers are typically used to measure gauge and differential pressures up to about 2 bar. The type of liquid used in the instrument depends on the pressure and characteristics of the fluid being measured. Water is an inexpensive and convenient choice, but it evaporates easily and is difficult to see. Nevertheless, it is used extensively, with the major obstacles to its use being overcome by using colored water and by regularly topping up the tube to counterast evaporation. However, water is definitely not used when measuring the pressure of fluids that react with or dissolve in water. Water is also unmitable when high pressure measurements are required. In such circumstances, liquids such as aniline, carbon tetrachloride, bromoform, mercury, or transformer oil are used instead.

15.7.2 Well-Type Manamoter (Clatern Manameter)

The well-type or cistern manometer, shown in Figure 15.6b, is samilar to a U-tube manometer but one-half of the tube is made very large so that is forms a well. The change in the level of the well as the measured pressure varies is negligible. Therefore, the liquid level in only one tube

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to be measured, thick makes the instrument much canier to use than the U-tube manometer, minimum pressure, p_1 , is applied to port A and port B is open to the atmosphere, the pressure is given by $p_1 = hp$. It might appear that the matrument would give better rement accuracy than the U-tube manometer because the need to subtract two liquid level mements in order to arrive at the pressure value is avoided. However, this benefit is remped by errors that arrive due to typical cross-nectional area variations in the glass used make the tube. Such variations do not affect the accuracy of the U-tube manometer to extent.

15.7.3 Inclined Manameter (Dreft Gauge)

The inclined manometer or draft gauge shown in Figure 15.6c is a variation on the well-type papemeter in which one leg of the tube is inclined to increase measurement sensitivity. However, similar comments to those given earlier apply about accuracy.

15.8 Resonant Wire Devices

A typical resonant wire device is shown achematically in Figure 15.7. Wire is stretched across a chamber containing fluid at unknown pressure subjected to a magnetic field. The wire resonates at its natural frequency according to its tension, which varies with pressure. Thus



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pressure is calculated by measuring the frequency of vibration of the wise. Such frequency measurement is normally carried out by electronics integrated into the cell. Such devices are highly accurate, with a typical inaccuracy figure being $\pm 0.2\%$ full-scale reading. They are also particularly insensitive to ambient condition changes and can measure pressures between 5 mbar and 2 bar.

15.9 Electronic Pressure Gauges

This section is included because many instrument manufacturers¹ catalogues have a action entitled "electronic pressure gauges." However, in reality, electronic pressure gauges are merely special forms of the pressure gauges described earlier in which electronic techniques are applied to improve performance. All of the following commonly appear in instrument catalogues under the heading "electronic pressure gauges."

Piezoresistive pressure transducer: This disploragm-type sensor uses piezoresistive strain gauges to measure disploragm displocement.

Piezoelectric pressure transducer: This displacementype sensor uses a piezoelectric crystal to measure displacement.

Magnetic pressure transducer: This class of disphragm-type device measures disphragm displacement magnetically using inductive, variable reluctance, or oddy current measures. *Capacitive pressure transducer*. This disphragm-type sensor measures variation in capacitance between the disphragm and a fixed metal plate close to it.

Fiber-optic pressure sensor: Known alternatively as an optical pressure sensor, this uses a fiber-optic sensor so measure the displacement of either a disphragm or a Bourdon tube pressure sensor.

Potentiometric pressure sensor: This is a device where the translational motion of a bellows-type pressure sensor is connected to the sliding element of an electrical potentiometer

Resonant pressure transducer: This is a form of resonant wise pressure-measuring device in which the pressure-induced frequency change is measured by electronics integrated into the device.

15.10 Special Measurement Devices for Low Pressures

The term vacuum gauge is applied commonly to describe any pressure sensor designed to measure pressures in the vacuum range (pressures less than atmospheric pressure, i.e., below 1.013 bar). Many special versions of the types of pressure transducers described earlier have been developed for measurement in the vacuum gauge. The typical minimum pressure measureable by these special forms of "normal" pressure-measuring instruments are 10 mbm (Boundos tubes), 0.1 subar (manometers and bellows-type instruments), and 0.001 gabar Sectoragens). However, in addition to these special versions of normal instruments, a member of other devices have been specifically developed for measurement of premures below emospheric pressure. These special devices include the thermocouple gauge, the Pirani use, the thermistor gauge, the McLood gauge, and the ionization gauge, and they are covered in more detail next. Unfortunately, all of these specialized instruments are quite expensive.

15.10.1 Thermocouple Gauge

The thermocouple gauge is one of a group of gauges working on the thermal conductivity principle. At low pressure, the kinematic theory of gause predicts a linear relationship between pressure and thermal conductivity. Thus measurement of thermal conductivity gives an indication of pressure. Figure 15.8 shows a sketch of a thermocouple gauge. Operation of the depends on the thermal conduction of hent between a thin hot metal strip in the center and the cold outer surface of a glass tube (that is normally at room temperature). The metal strip is bested by passing a current through it and its temperature is measured by a thermocouple. The temperature measured depends on the thermal conductivity of the gas in the tube and hence on its pressure. A source of error in this instrument is the fact that heat is also transferred by radiation as well as conduction. This error is of a constant magnitude, independent of pressure. Hence, it can be measured, and thus correction can be made for it. However, it is usually more convenient to design for low radiation loss by choosing a heated element with low emissivity. Thermocouple gauges are typically used to measure pressures in the range 10⁻⁴ mbar up to 1 mbar.



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15.10.2 Thermister Gauge

This is identical in its mode of operation to a thermocouple gauge except that a thermistor is used to measure the temperature of the metal strip rather than a thermocouple. It is commonly marketed under the name *electronic vacuum gauge* in a form that includes a digital light-emitting diode display and switchable output ranges.

15.10.3 Pirani Gauge

A typical form of Pirani gauge is shown in Figure 15.9a. This is similar to a thermocouple gauge but has a heated element that consists of four coiled tungsten wires connected in parallel. Two identical tubes are normally used, connected in a bridge circuit, as shown in Figure 15.9b, with one containing the gas at unknown pressure and the other evacuated to a very low pressure. Current is passed through the tungsten element, which attains a certain temperature according to the thermal conductivity of the gas. The resistance of the element changes with temperature and causes an imbalance of the measurement bridge. Thus, the Pirani gauge avoids the use of a thermocouple to measure temperature (as in the thermocouple gauge) by effectively using a resistance thermometer as the heated element. Such gauges cover the pressure range 10⁻⁵ to 1 mbar.

15.10.4 McLood Gauge

Figure 15.10s shows the general form of a McLeod gauge in which low-pressure fluid is compressed to a higher pressure that is then read by manometer techniques. In essence, the gauge can be visualized as a U-tube manometer that is sealed at one end and where the bottom







Other low-pressure gauges: (a) McLeod gauge and (b) ionization gauge.

of the U can be blocked at will. To operate the gauge, the piston is first withdrawn. This causes the level of mercury in the lower part of the gauge to fall below the level of junction J hetween the two tubes marked Y and Z in the gauge. Fluid at unknown pressure P_n is then introduced via the tube marked Z, from where it also flows into the tube of cross-sectional area A marked Y. Next, the piston is pushed in, moving the mercury level up to block junction J. At the mage where J is just blocked, the fluid in tube Y is at pressure P_n and is contained in a known volume, V_n . Further movement of the piston compresses the fluid in tube Y and this process continues until the mercury level in tube Z reaches a zero mark. Measurement of the height (h) above the mercury column in tube Y then allows calculation of the compressed volume of the fluid, V_m as $V_c = hA$.

Then, by Boyle's law: $P_{a}V_{a}=P_{a}V_{a}$

Also, applying the normal manometer equation, $P_c = P_u + h\rho_R$, where p is the mass density of mesoury, the pressure, P_m can be calculated as

$$= \frac{Ah^2 \rho_R}{V_e - Ah}$$
(15.1)

Compressed volume V_d is often very much smaller than the original volume, in which case liquation (15.1) approximates to

$$P_{\mu} = \frac{Ah^2 \rho g}{V_{\mu}} \quad \text{for } Ah << V_{\mu} \tag{15.2}$$

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Although the smallest inaccuracy achievable with McLeod gauges is $\pm 1\%$, this is still better than that achievable with most other gauges available for measuring pressures in this range. Therefore, the McLeod gauge is often used as a standard against which other gauges are calibrated. The minimum pressure normally measurable is 10^{-1} mbar, although lower pressures can be measured if pressure-dividing techniques are applied.

15.10.5 Ionization Gauge

The ionization gauge is a special type of instrument used for measuring very low pressures in the range 10⁻¹⁰ to 1 mbar. Normally, they are only used in laboratory conditions because their calibration is very sensitive to the composition of the gases in which they operate, and use of a mass spectrometer is often necessary to determine the gas composition around them. They exist in two forms known as a hot cathode and a cold cathode. The hot cathode form is shown achematically in Figure 15.10b. In this, gas of unknown pressure is introduced into a glass vessel containing free electrons discharged from a heated filament, as shown in Figure 15.10b. Gas pressure is determined by measuring the current flowing between an anode and a cathode within the vessel. This current is proportional to the number of ions per unit volume, which m turn is proportional to the gas pressure. Cold cathode ionization gauges operate in a similar fashion except that the stream of electrons is produced by a high voltage electrical discharge.

15.11 High-Pressure Measurement (Greater than 7000 bar)

Measurement of pressures above 7000 bar is normally carried out electrically by monitoring the change of resistance of wires of special materials. Materials having resistance pressure characteristics that are suitably linear and sensitive include manganin and gold-chromium alloys. A coil of such wire is enclosed in a scaled, kerosene-filled, flexible bellows, as shown in Figure 15.11. The unknown pressure is applied to one end of the bellows, which transmit pressure to the coil. The magnitude of the applied pressure is then determined by measuring the coil resistance. Devices are often named according to the metal used in them, for example. *manganin wire pressure sensor* and *gold-chromium wire pressure sensor*. Pressures up to 30,000 bar can be measured by devices such as the manganin wire pressure sensor, with a typical inaccuracy of $\pm 0.5\%$.

15.12 Intelligent Pressure Transducers

Adding microprocessor power to pressure transducers brings about substantial improvements in their characteristics. Measurement neusitivity improvement, extended measurement rangecompensation for bysteresis and other nonlinearities, and corraction for ambient temperature and pressure changes are just some of the facilities offered by intelligent pressure transducers.

Pressure Meanmaner 413



High-pressure measurement; wire coil in bellows

For example, inaccuracy values as low as $\pm 0.1\%$ can be achieved with silicon piezoresistiveindex devices.

Inclusion of microprocessors has also enabled the use of novel techniques of displacement manuferement, for example, the optical method of displacement measurement shown in Figure 15.12. In this, the motion is transmitted to a vane that progressively shades one of two monstituic photodiodes exposed to infrared radiation. The second photodiode acts as a reference, enabling the microprocessor to compute a ratio signal that is linearized and is available as either an analogue or a digital measurement of pressure. The typical rocamerement incouracy is $\pm 0.1\%$. Versions of both displacages and Bourdon tubes that use this technique are available.

15.13 Differential Pressure-Measuring Devices

Differential pressure-measuring devices have two input ports. One unknown pressure is applied to each port, and instrument output is the difference between the two pressures. An alternative to measure differential pressure would be to measure each pressure with a separate instrument and then subtract one reading from the other. However, this would produce a far less focusate measurement of the differential pressure because of the well-known problem that the process of subtracting measurements amplifies the inherent inaccuracy in each individual instrument. This is a particular problem when measuring differential pressures of low

Differential pressure can be measured by special forms of many of the pressure-measuring devices described earlier. Displarages pressure sensors, and their plezorestative, plezoelectric, impactic, capacitive, and fiber-optic named variants, are all commonly available is a



Example of an intelligent pressure-measuring instrument.

differential-pressure-measuring form in which the two pressures to be subtracted are applied to either side of the diaphragm. Double-bellows pressure transducers (including devices known as potentiometric pressure transducers) are also used, but are much less common than diaphragmbased sensors. A special form of U-tube manometer is also sometimes used when a visual indication of differential pressure values is required. This has the advantage of being a passive instrument that does not require a power supply and it is used commonly in liquid flow-rate indication.

15.14 Selection of Pressure Sensors

Choice between the various types of instruments available for measuring midrange pressure (1.013-7000 bar) is usually strongly influenced by the intended application. Manometers are used commonly when just a visual indication of pressure level is required, and dead-weight because of their superior accuracy, are used in calibration procedures of other manure-measuring devices. When an electrical form of output is required, the choice is usually either one cut of the several types of displacem sensors (strain gauge, piezoresistive, inconfecturic, magnetic, capacitive, or fiber optic) or, less commonly, a Bourdon tube. pellows-type instruments are also sometimes used for this purpose, but much less frequently. If very high measurement accuracy is required, the resonant wire device is a popular choice.

In the case of pressure measurement in the vacuum range (less than atmospheric pressure, i.e., below 1.013 bar), adaptations of most of the types of pressure transducers described earlier can be used. Special forms of Bourdon tubes measure pressures down to 10 mbar, measuremeters and bellows-type instruments measure pressures down to 0.1 mbar, and disphragms can be designed to measure pressures down to 0.001 mbar. However, a number of more specialized instruments have also been developed to measure vacuum pressures, as discussed in Section 15.10. These generally give better measurement accuracy and eatsitivity compared with instruments that are designed primarily for measuring midrange pressures. This improved accuracy is particularly evident at low pressures. Therefore, only the special instruments described in Section 15.10 are used to measure pressures below 10^{-4} mbar.

As high pressures (>7000 bar), the only devices in common use are the manganin wire senser and similar devices based on alternative alloys to manganin.

For differential pressure measurement, displantgen-type sensors are the preferred option, with fouble-bellows sensors being used occasionally. Manometers are also sometimes used to give visual indication of differential pressure values (ospecially in liquid flow-rate indicators). These are passive instruments that have the advantage of not needing a power supply.

15.15 Calibration of Pressure Sensors

Different types of reference instruments are used according to the range of the pressure measuring instrument being calibrated. In the midrange of pressures from 0.1 mbar to 20 bar, U-table manometers, dead-weight gauges, and barometers can all be used as reference instruments for calibration purposes. The vibrating cylinder gauge also provides a very accurate reference madered over part of this range. At high pressures above 20 bar, a gold-chrome alloy reastance reference instrument is normally used. For low pressures in the range of 10^{-4} to 10^{-3} mbar, but the McLeod gauge and various forms of microranometers are used as a pressure-measuring madered. At even lower pressures below 10^{-3} mbar, a pressure-dividing technique is used to combine calibration. This involves setting up a series of ortifices of an accurately known pressure ratio and measuring the upstream promate with a McLeod gauge or microranometer.

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The limits of accuracy with which pressure can be measured by presently known techniques are as follows:

 10^{-7} mbar
 $\pm 4\%$
 10^{-5} mbar
 $\pm 2\%$
 10^{-3} mbar
 $\pm 1\%$
 10^{-1} mbar
 $\pm 0.1\%$

 1 bar
 $\pm 0.001\%$
 10^4 bar
 $\pm 0.1\%$

15.15.1 Reference Calibration Instruments

Dood-weight gauge (pressure balance)

The dead-weight gauge, also known by the alternative names of *piston gauge* and *pressure* balance, is shown in schematic form in Figure 15.13. It is a null-reading type of measuring instrument in which weights are added to the piston platform until the piston is adjacent to a fixed reference mark, at which time the downward force of the weights on top of the piston is balanced by the pressure exerted by the fluid beneath the piston. The fluid pressure is therefore calculated in terms of the weight added to the platform and the known area of the piston. The instrument offers the ability to measure pressures to a high degree of accuracy and is widely used as a reference instrument against which other pressure-measuring instruments are calibrated in the midninge of pressures. Unfortunately, its mode of measurement makes it inconvenient to use and is therefore rarely used except for calibration duties.

Special precautions are necessary in the manufacture and use of dead-weight gauges. Friction between the piston and the cylinder must be reduced to a very low level, as otherwise a significant measurement error would result. Friction reduction is accomplished by designing for a small clearance gap between the piston and the cylinder by machining the cylinder to a slightly greater diameter than the piston. The piston and cylinder are also designed so that they



Schematic representation of a dead-weight gauge.

can be turned relative to one another, which reduces friction still further. Unfortunately, as a result of the small gap between the piston and the cylinder, there is a finite flow of fluid past the seals. This produces a viscous shear force, which partly balances the dead weight on the platform. A theoretical formula exists for calculating the magnitude of this shear force, suggesting that exact correction can be made for it. In practice, however, the piston deforms ander pressure and alters the piston/cylinder gap and so shear force calculation and correction can only be approximate.

Despite these difficulties, the instrument gives a typical measurement inaccuracy of only $\pm 0.01\%$. It is normally used for calibrating pressures in the range of 20 mbar up to 20 bar. However, special versions can measure pressures down to 0.1 mbar or up to 7000 bar.

U-tube manometer

In addition to its use for normal process measurements, the U-tube manometer is also used as a reference instrument for calibrating instruments measuring midrange pressures. Although it is a deflection rather than null type of instrument, it manages to achieve similar degrees of pasurement accuracy to the dead-weight gauge because of the error sources noted in the laner. The major source of error in U-tube manometers arises out of the difficulty in estimating the meniscus level of the liquid column accurately. There is also a tendency for the liquid level to preep up the tube by capillary action, which creates an additional source of error.

U tubes for measuring high pressures become unwieldy because of the long lengths of liquid rolumn and tube required. Consequently, U-tube manometers are normally used only for milibrating pressures at the lower end of the midpressure range.

Barowsters

The most commonly used type of barometer for calibration duties is the Fortin barometer. This is a highly accurate instrument that provides measurement inaccuracy levels of between ± 0.03 and $\pm 0.001\%$ of full-scale reading depending on the measurement range. To achieve such levels of accuracy, the instrument has to be used under very carefully controlled conditions of lighting, temperature, and vertical alignment. It must also be manufactured to exacting mandards and is therefore very expensive to buy. Corrections have to be made to the output reading according to ambient temperature, local value of gravity, and atmospheric pressure. Because of its expense and difficulties in using it, the barometer is not normally used for calibration other than as a primary reference standard at the top of the calibration chain.

Vibrating cylinder gauge

The vibrating cylinder gauge, shown in Figure 15.14, acts as a reference standard instrument for insting pressure measurements up to 3.5 bar. It consists of a cylinder in which vibrations an resonant frequency are excited by a current-carrying coll. The pressure-dependent cullation frequency is monitored by a pickup coil, and this frequency measurement is





Vibrating cylinder gauge.

converted to a voltage signal by a microprocessor and signal conditioning circuitry contained within the package. By evacuating the space on the outer side of the cylinder, the instrument is able to measure the absolute pressure of the fluid inside the cylinder. Measurement errors are leas than 0.005% over the absolute pressure range up to 3.5 bar.

Gold-chrome alloy resistance instruments

For measuring pressures above 7000 bar, an instrument based on measuring the resistance change of a metal coil as the pressure varies is used, and the same type of instrument is also used for calibration purposes. Such instruments commonly use manganin or gold-chrome alloys for the coil. Gold-chrome has a significantly lower temperature coefficient (i.e., its pressure/ resistance characteristic is less affected by temperature changes) and is therefore the normal choice for calibration instruments, despite its higher cost. An inaccuracy of only $\pm 0.1\%$ is achievable in such devices.

McLood gauge

The McLeod gauge, which has already been discussed earlier in Section 15.10, can be used for the calibration of instruments designed to measure low pressures between 10^{-4} and 0.1 mbar $(10^{-7} \text{ to } 10^{-4} \text{ bar})$.

Ionization gauge

An ionization gauge is used to calibrate instruments measuring very low pressures in the range 10^{-13} to 10^{-3} bar. It has the advantage of having a straight-line relationship between output reading and pressure. Unfortunately, its inherent accuracy is relatively poor, and specific points on its output characteristic have to be calibrated against a McLeod gauge.



Centrifugal micromanometer

Micromanometers

Micromanometers are instruments that work on the manometer principle but are specially designed to minimize capillary effects and meniscus reading errors. The centrifugal form of a micromanometer, shown schematically in Figure 15.15, is the most accurate type for use as a calibration standard down to pressures of 10^{-3} mbar. In this, a rotating disc serves to amplify a reference pressure, with the speed of rotation being adjusted until the amplified pressure just balances the unknown pressure. This null position is detected by observing when oil droplets sprayed into a glass chamber cease to move. Measurement inaccuracy is $\pm 1\%$.

Other types of micromanometers also exist, which give similar levels of accuracy, but only at somewhat higher pressure levels. These can be used as calibration standards at pressures up us 50 mbar.

15.15.2 Calculating Frequency of Calibration Checks

Some pressure-measuring instruments are very stable and unlikely to suffer drift in characteristics with time. Devices in this class include resonant wire devices, ionization gauges, and high pressure instruments (those working on the principle of resistance change with pressure). All forms of manometers are similarly stable, although small errors can develop in these through volumetric changes in the glass in the longer term. Therefore, for all these instruments, only

annual calibration checks are recommended, unless of course something happens to the instrument that puts its calibration into question.

However, most instruments used to pressure consist of an elastic element and a displacement transducer that measures its movement. Both of these component parts are mechanical in nature. Devices of this type include displaragms, bellows, and Bourdon tubes. Such Instruments can suffer changes in characteristics for a number of reasons. One factor is the characteristics of the operating environment and the degree to which the instrument is exposed to it. Another reason is the amount of mishandling they receive. These parameters are entirely dependent on the particular application the instrument is used in and the frequency with which it is used and exposed to the operating environment. A suitable calibration frequency can therefore only be determined on an experimental basis.

A third class of instrument from the calibration requirements viewpoint is the range of devices working on the thermal conductivity principle. This range includes the thermocouple gauge, Pirani gauge, and thermistor gauge. Such instruments have characteristics that vary with the nature of the gas being measured and must therefore be calibrated each time that they are used.

15.15.3 Procedures for Calibration

Pressure calibration requires the output reading of the instrument being calibrated to be compared with the output reading of a reference standard instrument when the same pressure is applied to both. This necessitates designing a suitable leakproof seal to connect the pressure measuring chambers of the two instruments.

The calibration of pressure transducers used for process measurements often has to be carried out in situ in order to avoid serious production delays. Such devices are often remote from the nearest calibration laboratory and to transport them there for calibration would take an unacceptably long time. Because of this, portable reference instruments have been developed for calibration at this level in the calibration chain. These use a standard air supply connected to an accurate pressure regulator to provide a range of reference pressures. An inaccuracy of $\pm 0.025\%$ is achieved when calibrating midrange pressures in this manner. Calibration at higher levels in the calibration chain must, of courte, be carried out in a proper calibration laboratory maintained in the correct manner. However, irrespective of where calibration is carried out, several special precautions are necessary when calibrating certain types of instrument, as described in the following paragraphs.

U-tube manometers must have their vertical alignment set up carefully before use. Particular care must also be taken to ensure that there are no temperature gradients across the two halves of the tube. Such temperature differences would cause local variations in the specific weight of the manometer fluid, resulting in measurement errors. Correction must also be made for the local value of g (acceleration due to gravity). These comments apply similarly to the use of other types of manometers and micromanometers.

The existence of one potentially major source of error in Bourdon tube pressure measurements has not been widely documented, and few manufacturers of Bourdon tubes make any attempt to warm users of their products appropriately. This problem is concerned with the relationship between the fluid being measured and the fluid used for calibration. The pointers of Bourdon tubes are normally set at zero during manufacture, using air as the calibration medium. However, if a different fluid, especially a liquid, is subsequently used with a Bourdon tube, the fluid in the tabe will cause a nonzero deflection according to its weight compared with air, resulting in a reading error of up to 6% of full-scale deflection.

This can be avoided by calibrating the Bourdon tube with the fluid to be measured instead of with air. Alternatively, correction can be made according to the calculated weight of the fluid in the tube. Unfortunately, difficulties arise with both of these solutions if air is trapped in the tube, as this will prevent the tube being filled completely by the fluid. Then, the amount of fluid actually is the tube, and its weight, will be unknown. To avoid this problem, at least one measurant uncertainties of less than 0.1% to be achieved.

When using a McLeod gauge, care must be taken to ensure that the measured gas does not contain any vapor. This would be condensed during the compression process, causing a measurement error. A further recommendation is insertion of a liquid—air cold trap between the gauge and the instrument being calibrated to prevent the passage of mercury vapor into the latter.

15.16 Summary

We started the chapter off by looking at the formal definitions of the three ways in which pressure is quantified in terms of absolute, gauge, and differential pressure. We then went on to look at the devices used for measuring pressure in three distinct ranges: normal, midrange pressures between 1.013 bar (the mean atmospheric pressure) and 7000 bar, low or vacuum pressures below 1.013 bar, and high pressures above 7000 bar.

We saw that a large number of devices are available for measurements in the "normal" range. Of these, sensors containing a diaphragm are used most commonly. We looked at the type of material used for the diaphragm in diaphragm-based sensors and also examined the different ways in which diaphragm movement can be measured. These different ways of measuring disphragm displacement give rise to a number of different names for diaphragm-based sensors. such as capacitive and fiber-optic (optical) sensors.

Moving on, we examined various other devices used to measure midrange pressures. These included bellows sensors, Bourdon tubes, several types of manometers, and resonant wire

sensors. We also looked at the range of devices commonly called electronic pressure gauges. Many of these are diaphragm-based sensors that use an electronic means of measuring diaphragm displacement, with names such as piezoresistive pressure sensor, piezoslectric pressure sensor, magnetic pressure sensor, and potentiometric pressure sensor.

We then weat on to study the measurement of low pressures. To start with, we observed that special forms of instruments used commonly to measure midrange pressures can measure pressures below atmospheric pressure instruments (Bourdon tabes down to 10 mbar, bellows, type instruments down to 0.1 mbar, manometers down to 0.1 mbar, and diaphragm-based sensors down to 0.001 mbar). As well as these special versions of Bourdon tabes, several other instruments have been specially developed to measure in the low-pressure range. These include thermocouple and thermistor gauges (measure between 10^{-5} and 1 mbar), the McLeod gauge (measures down to 10^{-1} mbar or even lower pressures if it is used in conjunction with pressure-dividing techniques), and the ionization gauge (measures between 10^{-10} to 1 mbar).

When we looked at measurement of high pressures, we found that our choice of instrument was much more limited. All currently available instruments for this pressure range involve monitoring the change of resistance in a coll of wire made from special materials. The two most common devices of this type are the manganin wire pressure sensor and gold-chromium wire pressure sensor.

The following three sections were devoted to intelligent pressure-measuring devices, instruments measuring differential pressure, and some guidance about which type of device to use in particular circumstances.

Then our final subject of study in the chapter was the means of calibrating pressure-measuring devices. We looked at various instruments used for calibration, including the dead-weight gauge, special forms of the U-tube manometers, barometers, the vibrating cylinder gauge, gold-chrome alloy resistance instruments, the McLeod gauge, the ionization gauge, and micromanometers. We then considered how the frequency of recalibration should be determined for various kinds of pressure-measuring devices. Finally, we looked in more detail at the appropriate practical procedures and precautions that should be taken for calibrating different types of instruments.

15.17 Problems

- 15.1. Explain the difference among absolute pressure, gauge pressure, and differential pressure. When pressure readings are being written down, what is the mechanism for defining whether the value is a gauge, absolute, or differential pressure?
- 15.2. Give examples of situations where pressure measurements are normally given as (a) absolute pressure, (b) gauge pressure, and (c) differential pressure.

- 15.3. Summarize the main classes of devices used for measuring absolute pressure.
- 15.4. Summarize the main classes of devices used for measuring gauge pressure.
- 15.5. Summarize the main classes of devices used for measuring differential pressure.
- 15.6. Explain what a diaphragm pressure sensor is. What are the different materials and in construction of a diaphragm pressure sensor and what are their relative merica?
- 15.7. Strain gauges are used commonly to measure displacement in a disphragm pressure sensor. What are the difficulties in bonding a standard strain gauge to the diaphragm and how are these difficulties usually solved?
- 15.8. What are the advantages in using a monolithic piezoresistive displacement transducer with diaphragm pressure sensors?
- 15.9. What other types of devices apart from strain gauges are used to measure displacement in a disphragm strain gauge? Summarize the main features of each of these alternative types of displacement measure.
- 15.10. Discuss the mode of operation of fiber-optic pressure sensors. What are their principal advantages over other forms of pressure sensors?
- 15.11. What are bellows pressure sensors? How do they work? Describe some typical applications.
- 15.12. How does a Bourdon tube work? What are the three common shapes of Bourdon tubes and what is the typical measurement range of each type?
- 15.13. Describe the three types of manometers available. What is the typical measurement range of each type?
- 15.14. What is a resonant wire pressure-measuring device and what is it typically used for?
- 15.15. What is an electronic pressure gauge? Discuss the different types of electronic gauges that exist.
- 15.16. Discuss the range of instruments available for measuring very low pressures (pressures below atmospheric pressure).
- 15.17. How are high pressures (pressures above 7000 bar) normally measured?
- 15.18. What advantages do intelligent pressure transducers have over their nonintelligent counterparts?
- 15.19. A differential pressure can be measured by subtracting the readings from two separate pressure transducers. What is the problem with this? Suggest a better way of measuring differential pressures.
- 15.20. How are pressure transducers calibrated? How is a suitable frequency of calibration datermined?
- 15.21. Which instruments are used as a reference standard in the calibration of pressure seasors?

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16.8 Problems 459

16.1 Introduction

We now move on to look at flow measurement in this chapter. Flow measurement is concerned with quantifying the rate of flow of materials. Such measurement is quite a common requirement in the process industries. The material measured may be in a solid, liquid, or gaseous state. When the material is in a solid state, flow can only be quantified as the mass flow rate, this being the mass of material that flows in one unit of time. When the material is in a liquid or gaseous state, flow can be quantified as either the mass flow rate or the volume flow rate, with the latter being the volume of material that flows in one unit of time. Of the two, a flow measurement in terms of mass flow rate is preferred if very accurate measurement is required. The greater accuracy of mass flow measurement arises from the fact that mass is invariant whereas volume is a variable quantity.

A particular complication in the measurement of flow rate of liquids and gases flowing in pipes is the need to consider whether the flow is laminar or turbulent. Laminar flow is characterized by a motion of the fluid being in a direction parallel to the sides of the pipe, and it occurs in straight lengths of pipe when the fluid is flowing at a low velocity. However, it should be noted that even laminar flow is not uniform across the cross section of the pipe, with the velocity being greatest at the center of the pipe and decreasing to zero immediately next to the wall of the pipe. In contrast, turbulent flow involves a complex pattern of flow that is not in a uniform direction. Turbulent flow occurs in nonstraight sections of pipe and also occurs in straight sections when the fluid velocity exceeds a critical value. Because of the difficulty in measuring turbulent flow, the usual practice is to restrict flow measurement to places where the flow is laminar, or at least approximately laminar. This can be achieved by measuring the flow in the center of a long, straight length of pipe if the flow velocity is below the critical velocity for turbulent flow. In the case of high meas fluid velocity, It is often possible to find somewhere within the flow path where a larger diameter pipe exists and therefore the flow velocity is lower.

16.2 Mass Flow Rate

The method used to measure mass flow rate is determined by whether the measured quantity is is a solid, liquid, or gaseous state, as different techniques are appropriate for each. The mean methodoles available for measuring mass flow rate are summarized here.

16.2.1 Conveyor-Based Methods

Conveyor-based methods are appropriate for measuring the flow of solids in the form of powders or small grasular particles. Such powders and particles are produced commonly by crushing or grinding procedures in process industries, and a conveyor is a very suitable means of transporting materials in this form. Transporting materials on a conveyor allows the mass flow rate to be calculated in terms of the mass of material on a given length of conveyor multiplied by the speed of the conveyor. Figure 16.1 shows a typical measurement system. A load cell measures the mass, *M*, of material distributed over a length, *L*, of the conveyor. If the conveyor velocity is *r*, the mass flow rate, *O*, is given by

$$Q = Mv/L.$$

As an alternative to weighing flowing material, a *nuclear mass-flow sensor* can be used, in which a y-ray source is directed at the material being transported along the conveyor. The material absorbs some radiation, and the amount of radiation received by a detector on the other side of the material indicates the amount of material on the conveyor. This technique has obvious safety concerns and is therefore subject to licensing and strict regulation.

16.2.2 Ceriolis Flowmeter

As well as sometimes being known by the alternative name of *inertial flowmeter*, the Coriolis flowmeter is often referred to simply as a *mass flowmeter* because of its dominance in the mass flowmeter market. However, this assumption that a mass flowmeter always refers to a Coriolis meter is wrong, as several other types of devices are available to measure mass flow. Although it is true to say that they are much less common than Coriolis meters.



Coriolis meters are used primarily to measure the mass flow rate of liquids, although they have also been used successfully in some gas-flow measurement applications. The flowmeter consists either of a pair of parallel vibrating tubes or as a single vibrating tube that is formed into a configuration that has two parallel sections. The two vibrating tubes (or the two parallel sections of a single tube) deflect according to the mass flow rate of the measured fluid that is flowing inside. Tubes are made of various materials, of which stainless steel is the most common. They are also manufactured in different shapes, such as B shaped, D shaped, U shaped, triangular shaped, helix shaped, and straight. These alternative shapes are akteched in Figure 16.2a, and a U-shaped tube is shown in more detail in Figure 16.2b. The tubes are two anchors, excites vibrations in each tube at the tube resonant frequency. Vibrations in the two tubes, or the two parallel sections of a single tube, are 180 degrees out of phase.



(a) Coriolis flowmeter shapes; (b) detail of U-shaped Coriolis flowmeter.

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The vibratory motion of each tube causes forces on the particles in the flowing fluid. These induce motion of the fluid particles in a direction that is orthogonal to the direction of two, which produces a Coriolis force. This Coriolis force causes a deflection of the tubes that is imposed on top of the vibratory motion. The net deflection of one tube relative to the other siven by d = kfR, where k is a constant, f is the frequency of the tube vibration, and R is the flow rate of the fluid inside the tube. This deflection is measured by a suitable sensor.

Coriolis meters give excellent accuracy, with measurement uncertainties of $\pm 0.2\%$ being original They also have low maintenance requirements. However, apart from being expensive (opical cost is \$6000), they suffer from a number of operational problems. Failure may occur a period of use because of mechanical fatigue in the tubes. Tubes are also subject to both composition caused by chemical interaction with the measured fluid and abrasion caused by matcles within the fluid. Diversion of the flowing fluid around the flowmeter causes it to suffer a significant pressure drop, although this is much less evident in straight tube designs.

16.2.3 Thermal Mess Flow Measurement

Thermal mass flowmeters are used primarily to measure the flow rate of gases. The principle of operation is to direct the flowing material past a heated element. The mass flow rate is inferred in one of two ways: (a) by measuring the temperature rise in the flowing material or (b) by measuring the heater power required to achieve a constant set temperature in the flowing material. In both cases, the specific heat and density of the flowing fluid must be known. Typical measurement uncertainty is $\pm 2\%$. Standard instruments require the measured gas to be clean and noncorrosive. However, versions made from special alloys can cope with more tegeressive gases. Tiny versions of thermal mass flowmeters have been developed that can measure very small flow rates in the range of nanoliters (10^{-6} liters) or microliters (10^{-6} liters) per minute.

16.2.4 Joint Measurement of Volume Flow Rate and Fluid Density

Before the advent of the Coriolis meter, the usual way of measuring the mass flow rate was to compute this from separate, simultaneous measurements of the volume flow rate and the flued density. In many circumstances, this is still the least expensive option, although measurements accuracy is substantially inferior to that provided by a Coriolis meter.

16.3 Volume Flow Rate

Volume flow rate is an appropriate way of quantifying the flow of all materials that are in a ganeous, liquid, or sensiliquid sturry form (where solid particles are suspended in a liquid hout), authough measurement accuracy is inferior to mass flow measurement as noted earlier. Materials in these forms are usually carried in pipes, and various instruments can be used to

measure the volume flow rate as described later. As noted in the introduction, these all assume laminar flow. In addition, flowing liquids are sometimes carried in an open channel, in which case the volume flow rate can be measured by an open channel flowmeter.

16.3.1 Differential Pressure (Obstruction-Type) Meters

Differential pressure meters involve the insertion of some device into a fluid-carrying pipe that causes an obstruction and creates a pressure difference on either side of the device. Such meters are sometimes known as obstruction-type meters or flow restriction meters. Devices used to obstruct the flow include the *orifice plate*, *Venturi tube*, *flow nozzle*, and *Dall flow tube*, as illustrated in Figure 16.3. When such a restriction is placed in a pipe, the velocity of the fluid through the restriction increases and the pressure decreases. The volume flow rate is then proportional to the square root of the pressure difference across the obstruction. The manner in which this pressure difference is measured is important. Measuring the two pressures with different instruments and calculating the difference between the two measurements is not satisfactory because of the large measurement error that can arise when the pressure difference is small, as explained in Chapter 3. Therefore, the normal procedure is to use a differential pressure transducer, which is commonly a disphragm-type device.

The pitot static tube is another device that measures flow by creating a pressure difference within a fluid-carrying pipe. However, in this case, there is negligible obstruction of flow in the pipe. The pitot tube is a very thin tube that obstructs only a small part of the flowing fluid and thus measures flow at a single point across the cross section of the pipe. This measurement





only equates to average flow velocity in the pipe for the case of uniform flow. The annubar is a type of multiport pitot tube that measures the average flow across the cross section of the pipe by forming the mean value of several local flow measurements across the cross section of the pipe.

All applications of this method of flow measurement assume laminar flow by ensuring that the flow conditions upstream of the obstruction device are in steady state; a certain minimum length of straight run of pipe shead of the flow measurement point is specified to achieve thus. The minimum lengths required for various pipe diameters are specified in standards tables. However, a useful rule of thumb widely used in process industries is to specify a length of 10 times the pipe diameter. If physical restrictions make this impossible to achieve, special flow-smoothing vanes can be inserted immediately ahead of the measurement point.

Flow restriction-type instruments are popular because they have no moving parts and are therefore robust, reliable, and easy to maintain. However, one significant disadvantage of this method is that the obstruction causes a permanent loss of pressure in the flowing fluid. The magnitude and hence importance of this loss depend on the type of obstruction element used, but where the pressure loss is large, it is sometimes necessary to recover the lost pressure by an auxiliary pump further down the flow line. This class of device is not normally suitable for measuring the flow of slurries, as the tappings into the pipe to measure the differontial pressure are prone to blockage, although the Venturi tube can be used to measure the flow of dilute slurries.

Figure 16.4 illustrates approximately the way in which the flow pattern is interrupted when an orifice plate is inserted into a pipe. Other obstruction devices also have a similar effect to this, although the magnitude of pressure loss is smaller. Of particular interest is the fact that the minimum cross-sectional area of flow occurs not within the obstruction but at a point downstrease of there. Knowledge of the pattern of pressure variation along the pipe, as shown in Figure 16.5.



Profile of flow across orifice plate



Pattern of pressure variation either side of orifice plate.

is also of importance in using this technique of volume-flow-rate measurement. This shows that the point of minimum pressure coincides with the point of minimum cross-section flow a little way downstream of the obstruction. Figure 16.5 also shows that there is a small rise in pressure immediately before the obstruction. It is therefore important not only to position the instrument measuring P_2 exactly at the point of minimum pressure, but also to measure the pressure P_1 at a point upstream of the point where the pressure starts to rise before the obstruction.

In the absence of any heat transfer mechanisms, and assuming frictionless flow of an incompressible fluid through the pipe, the theoretical volume flow rate of the fluid, Q, is given by

$$Q = \left[\frac{A_2}{\sqrt{1 - (A_2/A_1)^2}}\right] \left[\sqrt{\frac{2(P_1 - P_2)}{\rho}}\right],$$
 (16.1)

where A_1 and P_1 are the cross-sectional area and pressure of the fluid flow before the obstruction. A_2 and P_2 are the cross-sectional area and pressure of the fluid flow at the narrowest point of the flow beyond the obstruction, and p is the fluid density.

Equation (16.1) is never entirely applicable in practice for two main reasons. First, the flow is always impeded by a friction force, which varies according to the type of fluid and its velocity and is quantified by a constant known as the Reynold's number. Second, the cross-sectional area of the fluid flow ahead of the obstruction device is less than the diameter of the pipe carrying it, and the minimum cross-sectional area of the fluid after the obstruction is less than the diameter of the obstruction. This latter problem means that neither A_1 nor A_2 can be measured accurately. Fortunately, provided the pipe is smooth and therefore the friction force is small, these two problems can be accounted for adequately by applying a constant called the discharge coefficient. This modifies Equation (16.1) to the following:

$$Q = \left| \frac{C_0 A'_2}{\sqrt{1 - (A'_2/A'_1)^2}} \right| \sqrt{\frac{2(P_1 - P_2)}{\rho}} \right|. \quad (16.2)$$

where A'_1 and A'_2 are the actual pipe diameters before and at the obstruction and C_D is the discharge coefficient that corrects for the friction force and the difference between the pipe and flow cross-section diameters.

Before Equation (16.2) can be evaluated, the discharge coefficient must be calculated. As this varies between each measurement situation, it would appear at first sight that the discharge coefficient must be determined by practical experimentation in every case. However, provided that certain conditions are met, standard tables can be used to obtain the value of the discharge coefficient appropriate to the pipe diameter and fluid involved.

One particular problem with all flow restriction devices is that the pressure drop, $(P_1 - P_2)$, varies, as the square of the flow rate Q according to Equation (16.2). The difficulty of measuring small pressure differences accurately has already been noted earlier. In consequence, the technique is only suitable for measuring flow rates that are between 30 and 100% of the maximum flow rate that a given device can handle. This means that alternative flow measurement techniques have to be used in applications where the flow rate can vary over a large range that can drop to below 30% of the maximum rate.

Orifice plate

The orifice plate is a metal disc with a concentric hole in it, which is inserted into the pipe carrying the flowing fluid. Orifice plates are simple, inexpensive, and available in a wide range of sizes. In consequence, they account for almost 50% of the instruments used in industry for measuring volume flow rate. One limitation of the orifice plate is that its innocuracy is typically at least $\pm 2\%$ and may approach $\pm 5\%$. Also, the permanent pressure loss caused in the measured fluid flow is between 50 and 90% of the magnitude of the pressure difference. (P - P) Other problems with the orifice plate are a gradual change in the discharge coefficient over a period of time as the sharp adges of the hole wear away and a tendency for any particles in the flowing fluid to stick behind the hole, thereby reducing its diameter gradually as the particles build up. The latter problem can be minimized by using an orifice plate with an eccentric hole. If this hole is close to the bottom of the pipe, solids in the

flowing fluid tend to be swept through, and buildup of particles behind the plate is minimized. A very similar problem arises if there are any bubbles of vapor or gas in the flowing fluid when liquid flow is involved. These also tend to build up behind an orifice plate and distort the pattern of flow. This difficulty can be avoided by mounting the orifice plate in a vertical run of pipe.

Venturis and similar devices

A number of obstruction devices are available that are specially designed to minimize pressure loss in the measured fluid. These have various names such as Venturi, flow nozzle, and Dall flow tube. They are all much more expensive than an orifice plate but have better performance. The smooth internal shape means that they are not prone to solid particles or bubbles of gas sticking in the obstruction, as is likely to happen in an orifice plate. The smooth shape also means that they suffer much less wear and, consequently, have a longer life than orifice plates. They also require less maintenance and give greater measurement accuracy.

Venturl: The Venturi has a precision-engineered tube of a special shape. This offers measurement uncertainty of only $\pm 1\%$. However, the complex machining required to manufacture it means that it is the most expensive of all the obstruction devices discussed. Permanent pressure loss in the measured system is 10-15% of the pressure difference $(P_1 - P_2)$ across it.

Dall flow tube: The Dall flow tube consists of two conical reducers inserted into a fluidcarrying pipe. It has a very similar internal shape to the Venturi, except that it lacks a throat. This construction is much easier to manufacture, which gives the Dall flow tube at advantage in cost over the Venturi, although the typical measurement inaccuracy is a little higher ($\pm 1.5\%$). Another advantage of the Dall flow tube is its shorter length, which makes the engineering task of inserting it into the flow line easier. The Dall tube has one further operational advantage in that the permanent pressure loss imposed on the measured system is only about 5% of the measured pressure difference ($P_1 - P_2$).

Flow nozzle: This nozzle is of simpler construction still and is therefore less expensive than either a Venturi or a Dall flow tube, but the pressure loss imposed on the flowing fluid is 30-50% of the measured pressure difference $(P_1 - P_2)$ across the nozzle.

Pitot static tube

The pitot static tube is used mainly for making temporary measurements of flow, although it is also used in some instances for permanent flow monitoring. It measures the local velocity of flow at a particular point within a pipe rather than the average flow velocity as measured by other types of flowmeters. This may be very useful where there is a requisement to measure local flow rates across the cross section of a pipe in the case of nonuniform flow. Multiple pitot tubes are normally used to do this.

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The instrument depends on the principle that a tube placed with its open end in a stream of fluid, as shown in Figure 16.6, will bring to rest that part of the fluid that impinges on it, and the loss of kinetic energy will be converted to a measurable increase in pressure inside the tube. This pressure (P_1) , as well as the static pressure of the undisturbed free stream of flow (P_2) , is measured. The flow velocity can then be calculated from the formula:

$$\mathbf{v} = C\sqrt{2g(P_1 - P_2)}.$$

The constant C, known as the pitot tube coefficient, is a factor that corrects for the fact that and all fluid incident on the end of the tube will be brought to rest, a proportion will slip around in according to the design of the tube. Having calculated v, the volume flow rate can then be calculated by multiplying v by the cross-sectional area of the flow pipe, A.

Pitot tables have the advantage that they cause negligible pressure loss in the flow. They are also inexpensive, and the installation procedure consists of the very simple process of pushing them down a small hole drilled in the flow-carrying pipe. Their main failing is that measurement innecuracy is typically about $\pm 5\%$, although more expensive versions can reduce innecuracy down to $\pm 1\%$. The *annubar* is a development of the pipe table that has multiple sensing ports distributed across the cross section of the pipe and thus provides an approximate measurement of the mean flow rate across the pipe.

16.3.2 Variable Area Flowmeters (Rotemeters)

In the variable area flowmeter (which is also nometimes known as a rotameter), the differential pressure across a variable sporture is used to adjust the area of the sporture. The sporture area is then a measure of the flow rate. The instrument is reliable, inexpensive, and used extensively throughout industry, accounting for about 20% of all flowmeters and. Normally, because this type of instrument only gives a visual indication of flow rate, it is of

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Variable area flowmeter.

no use in automatic control schemes. However, special versions of variable area flowmeters are now available that incorporate fiber optics. In these, a row of fibers detects the position of the float by sensing the reflection of light from it, and an electrical signal output can be derived from this.

In its simplest form, shown in Figure 16.7, the instrument consists of a tapered glass tube containing a float that takes up a stable position where its submerged weight is balanced by the up thrust due to the differential pressure across it. The position of the float is a measure of the effective annular area of the flow passage and hence of the flow rate. The inaccuracy of the least expensive instruments is typically $\pm 5\%$, but more expensive versions offer measurement inaccuracies as low as $\pm 0.5\%$.

16.3.3 Positive Displacement Flowmeters

Positive displacement flowmeters account for nearly 10% of the total number of flowmeters used in industry and are used in large numbers for metering domestic gas and water communiption. The least expensive instruments have a typical inaccuracy of about $\pm 2\%$, but the inaccuracy in more expensive ones can be as low as $\pm 0.5\%$. These higher quality instruments are used extensively within the oil industry, as such applications can justify the high cost of such instruments.

nositive displacement meters operate using mechanical divisions to displace discrete olumes of fluid nuccessively. While this principle of operation is common, many different transfeat arrangements exist for putting the principle into practice. However, all versions of displacement meters are low friction, low maintenance, and long life devices, although they do impose a small permanent pressure loss on the flowing fluid. Low friction is especially important when measuring gas flows, and meters with special mechanical arrangements to estisfy this requirement have been developed.

The rotary piston meter is a common type of positive displacement meter used particularly for the measurement of domestic water supplies. It consists, as shown in Figure 16.8, of a slotted cylindrical piston moving inside a cylindrical working chamber that has an inlet post and an outlet port. The piston moves round the chamber such that its outer surface maintains contact with the inner surface of the chamber, and, as this happens, the piston slot slides up and down a fixed division plate in the chamber. At the start of each piston motion cycle, liquid is admitted to volume B from the inlet port. The fluid pressure causes the piston to start to rotate around the chamber, and, as this happens, liquid in volume C starts to flow out of the outlet port, and also liquid starts to flow from the inlet port into volume A. As the piston rotates further, volume B becomes shut off from the inlet port, while liquid continues to be admitted into A and pushed out of C. When the piston reaches the end point of its motion cycle, the outlet port is opened to volume B, and the liquid that has been transported round inside the piston is expelled. After this, the piston pivots about the contact point between the top of its slot and the division plate, and volume A effectively becomes volume C rendy lur



Rotary piston form of positive displacement flowmeter.

the start of the next motion cycle. A peg on top of the piston causes a reciprocating motion of a lever attached to it. This is made to operate a counter, and the flow rate is therefore determined from the count in unit time multiplied by the quantity (fixed) of liquid transferred between inlet and outlet ports for each motion cycle.

The nutating disk meter is another form of positive displacement meter in which the active element is a disc inside a precision-machined chamber. Liquid flowing into the chamber causes the disc to nutate (wobble), and these nutations are translated into a rotary motion by a roller cam. Rotations are counted by a pulse transmitter that provides a measurement of the flow rate. This form of meter is noted for its ruggedness and long life. It has a typical measurement accuracy of $\pm 1.0\%$. It is used commonly for water supply measurement.

The oval gear meter is yet another form of positive displacement meter that has two ovalshaped gear wheels. It is used particularly for measuring the flow rate of high viscosity fluids. It can also cope with measuring fluids that have variable viscosity.

16.3.4 Turbine Meters

A turbine flowmeter consists of a multibladed wheel mounted in a pipe along an axis parallel to the direction of fluid flow in the pipe, as shown in Figure 16.9. The flow of fluid past the wheel causes it to rotate at a rate proportional to the volume flow rate of the fluid. This rate of rotation has traditionally been measured by constructing the flowmeter such that it behaves as a variable reluctance tachogenerator. This is achieved by fabricating the tarbine blades from a ferromagnetic material and placing a permanent magnet and coil inside the meter housing. A voltage pulse is induced in the coil as each blade on the turbine wheel moves past it.



and if these pulses are measured by a pulse counter, the pulse frequency and hence flow rate can be deduced. In recent instruments, fiber optics are also now sometimes used to count the rotations by detecting reflections off the tip of the turbine blades.

Provided that the turbine wheel is mounted in low-friction bearings, measurement inaccuracy can be as low as $\pm 0.2\%$. However, turbine flowmeters are less rugged and reliable than flow particulation-type instruments and are affected badly by any particulate matter in the flowing fluid. Bearing wear is a particular problem, which also imposes a permanent pressure loss on the measured system. Turbine meters are particularly prone to large errors when there is any significant second phase in the fluid measured. For instance, using a turbine meter calibrated on pure liquid to measure a liquid containing 5% air produces a 50% measurement error. As an important application of the turbine meter is in the petrochemical industries, where gas/oil mixtures are common, special procedures are being developed to avoid such large measurement errors.

Readers may find reference in manufacturers' catalogues to a Wolmann meter. This is a type of turbine meter that has belical blades and is used particularly for measuring high flow rates. It is also sometimes known as a *helix meter*,

Turbine meters have a similar cost and market share to positive displacement meters and compete for many applications, particularly in the oil industry. Turbine meters are smaller and lighter than the latter and are preferred for low-viscosity, high-flow measurements. However, positive displacement meters are superior in conditions of high viscosity and low flow rate.

16.3.5 Electromagnetic Flowmeters

Electromagnetic flowmeters, sometimes known just as magnetic flowmeters, are limited to measuring the volume flow rate of electrically conductive fluids. A typical measurement insecuracy of around $\pm 1\%$ is acceptable in many applications, but the instrument is expensive both in terms of the initial purchase cost and in running costs, mainly due to its electricity consumption. A further reason for its high cost is the meed for careful calibration of each instrument individually during manufacture, as there is considerable variation in the properties of the magnetic materials used.

The instrument, shows in Figure 16.10, consists of a stainless steel cylindrical tube fitted with an insulating liner, which carries the measured fluid. Typical lining materials used are neoprese, cylindrical tube fitted with an insulating liner, which carries the measured fluid. Typical lining materials used are neoprese, cylindrical tube fitted with an insulation of fluid coils either side of it, and the voltage induced in the fluid is measured by two electrodes inserted into opposite sides of the tube. The ends of these electrodes are usually flush with the inner surface of the cylinder. The electrodes are constructed from a material that in traffected by most types of flowing fluids, such as stainless steel, platinum-iridium alloys,



Figure 16.10 Electromagnetic flowmeter.

Hastelloy, litanium, and tantalum. In the case of rarer metals in this list, the electrodes account for a significant part of the total instrument cost.

By Faraday's law of electromagnetic induction, the voltage, E, induced across a length, L, of the flowing fluid moving at velocity, v, in a magnetic field of flux density, B, is given by

$$\boldsymbol{E} = \boldsymbol{B} \boldsymbol{L} \boldsymbol{v}, \tag{16.3}$$

where L is the distance between the electrodes, which is the diameter of the tube, and B is a known constant. Hence, measurement of voltage E induced across the electrodes allows flow velocity v to be calculated from Equation (16.3). Having thus calculated v, it is a simple matter to smalliply v by the cross-nectional area of the tube to obtain a value for the volume flow rate. The typical voltage signal measured across the electrodes is 1 mV when the fluid flow rate is 1 m/s.

The internal diameter of electromagnetic flowmeters is normally the same as that of the rest of the flow-carryiag pipe work in the system. Therefore, there is no obstruction to fluid flow

t consequently no pressure loss is associated with measurement. Like other forms of meters, the electromagnetic type requires a minimum length of straight pipe work to the point of flow measurement in order to guarantee the accuracy of measurement, although a length equal to five pipe diameters is usually sufficient.

While the flowing fluid must be electrically conductive, the method is of use in many applications and is particularly useful for measuring the flow of slurries in which the liquid base is electrically conductive. Corrosive fluids can be handled, providing a suitable lining material is used. At the present time, electromagnetic flowmeters account for about 15% of the new flowmeters sold and this total is slowly growing. One operational problem is that the insulating lining is subject to damage when abrasive fluids are being handled, which can give the instrument a limited life.

New developments in electromagnetic flowmeters are producing instruments that are physically smaller than before. Also, by employing better coil designs, electricity consumption is reduced. This means that battery-powered versions are now available commercially. Also, whereas conventional electromagnetic flowmeters require a minimum fluid conductivity of 10 µmho/cm³, new versions can cope with fluid conductivities as low as 1 µmho/cm³,

16.3.6 Vertex-Shedding Flowmeters

The vortex-shedding flowmeter is used as an alternative to traditional differential pressure meters in many applications. The operating principle of the instrument is based on the natural phenomenon of vortex shedding, created by placing an unstreamlined obstacle (known as a bluff body) in a fluid-carrying pipe, as indicated in Figure 16.11. When fluid flows past the obstacle, boundary layers of viscous, slow-moving fluid are formed along



Vortex-shedding flowmeter.

the outer surface. Because the obstacle is not streamlined, the flow cannot follow the contours of the body on the downstream side, and the separate layers become detached and roll into eddies or vortices in the low-pressure region behind the obstacle. The shedding frequency of these alternately shed vortices is proportional to the fluid velocity past the body. Various thermal, magnetic, ultrasonic, and capacitive vortex detection techniques are employed in different instruments.

Such instruments have no moving parts, operate over a wide flow range, have low power consumption, require little maintenance, and have a similar cost to measurement using an orifice plate. They can measure both liquid and gas flows, and a common inaccuracy value quoted is $\pm 1\%$ of full-scale reading, although this can be seriously downgraded in the presence of flow distarbances upstream of the measurement point and a straight run of pipe before the measurement point of 50 pipe diameters is recommended. Another problem with the instrument is its susceptibility to pipe vibrations, although new designs are becoming available that have a better immunity to such vibrations.

16.3.7 Ultrasonic Flowmsters

The ultrasonic technique of volume flow rate measurement is, like the magnetic flowmeter. a noninvasive method. It is not restricted to conductive fluids, however, and is particularly useful for measuring the flow of corrosive fluids and slurries. In addition to its high reliability and low maintenance requirements, a further advantage of an ultrasonic flowmeter over an electromagnetic flowmeter is that the instrument can be clamped externally onto existing pipe work instead of being inserted as an integral part of the flow line. As the procedure of breaking into a pipeline to insert a flowmeter can be as expensive as the cost of the flowmeter isalf, the ultrasonic flowmeter has enormous cost advantages. Its clamp-on mode of operation also has significant safety advantages in avoiding the possibility of personnel installing flowmeters coming into contact with hazardous fluids, such as poisonous, radioactive, flammable, or explosive ones. Also, any contamination of the fluid being measured (e.g., food substances and drugs) is avoided. Ultrasonic meters are still less common than differential pressure or electromagnetic flowmeters, although usage continuexto expand year by year.

Two different types of ultrasonic flowmeter exist that employ distinct technologies—one based on Doppler shift and the other on transit time. In the past, the existence of these alternative technologies has not always been readily understood and has resulted in ultrasonic technology being rejected entirely when one of these two forms has been found to be unsatisfactory in a particular application. This is unfortunate because the two technologies have distinct characteristics and areas of applications, and many situations exist where one form is very suitable and the other is not. To reject both, having only tried out one, is therefore a serious mistake. Ultrasonic flowmeters have become available that combine both Doppler shift and transit time technologies. esticular care has to be taken to ensure a stable flow profile in ultrasonic flowmeter applications. In usual to increase the normal specification of the minimum length of straight pipe run prior to the point of measurement, expressed as a number of pipe diameters, from a value of 10 up to 20 or, in some cases, even 50 diameters. Analysis of the reasons for poor performance in many instances of ultrasonic flowmeter application has shown failure to meet this stable flow profile requirement to be a significant factor,

Doopler shift ultrasonic flowmeter

The principle of operation of the Doppler shift flowmeter is shown in Figure 16.12, A landamental requirement of these instruments is the presence of scattering elements within the flowing fluid, which deflect the ultrasonic energy output from the transmitter such that it esters the receiver. These can be provided by solid particles, gas bubbles, or eddies in the flowing fluid. The scattering elements cause a frequency shift between transmitted and metered altrasonic energy, and measurement of this shift enables fluid velocity to be inferred.

The instrument consists essentially of an ultrasonic transmitter-receiver pair clamped onto the outside wall of a fluid-carrying vessel. Ultrasonic energy consists of a train of short bursts of instoidal waveforms at a frequency between 0.5 and 20 MHz. This frequency range is described as ultrasonic because it is outside the range of human hearing. The flow velocity, v, is given by



Doppler shift ultrasonic flowmeter.

$$=\frac{c(f_{1}-f_{2})}{2f_{1}\cos(\theta)},$$
 (16.4)

where f_i and f_r are the frequencies of the transmitted and received ultrasonic waves, tespectively c is the velocity of sound in the fluid being measured, and θ is the angle that the incident and reflected energy waves make with the axis of flow in the pipe. Volume flow rate is then calculated readily by multiplying the measured flow velocity by the cross-sectional area of the fluid-carrying pipe.

The electronics involved in Doppler shift flowmeters is relatively simple and therefore inexpensive. Ultrasonic transmitters and receivers are also relatively inexpensive, being based on piezoelectric oscillator technology. Therefore, as all of its components are inexpensive, the Doppler shift flowmeter itself is inexpensive. The measurement accuracy obtained depends un many factors, such as the flow profile; the constancy of pipe wall thickness; the number, size, and spatial distribution of scatterers; and the accuracy with which the speed of sound in the fluid is known. Consequently, accurate measurement can only be achieved by the tedious procedure of carefully calibrating the instrument in each particular flow measurement application. Otherwise, measurement errors can approach ± 10% of the reading; for this reason, Doppler shift flowmeters are often used merely as flow indicators rather than for accurate quantification of the volume flow rate.

Versions are now available that are being fitted inside the flow pipe, flush with its inner surface. This overcomes the problem of variable pipe thickness, and an inaccuracy level as small as $\pm 0.5\%$ is claimed for such devices. Other recent developments are the use of multiple path ultrasonic flowmeters that use an array of ultrasonic elements to obtain an average velocity measurement. This reduces error due to nonuniform flow profiles substantially but there is a substantial cost penalty involved in such devices.

Transit time ultresonic flowmeter

A transit time ultrasonic flowmeter is an instrument designed for measuring the volume flow rate in clean liquids or games. It consists of a pair of ultrasonic transducers mounted along an axis aligned at angle θ with respect to the fluid flow axis, as shown in Figure 16.13,

Each transducer consists of a transmitter-receiver pair, with the transmitter emitting ultrasonic energy that travels across to the receiver on the opposite side of the pipe. These ultrasonic elements are normally piezoelectric oscillators of the same type used in Doppler shift flowmeters. Fluid flowing in the pipe causes a time difference between the transit times of beams traveling upstream and downstream, and measurement of this difference allows the flow velocity to be calculated. The typical magnitude of this time difference is 100 m in a total transit time of 100 µs, and high-precision electronics are therefore needed to measure the difference. There are three distinct ways of measuring the time shift. These are direct measurement, conversion to a phase



Figure 16.13 Transit time ultrasonic flowmeter.

change, and conversion to a frequency change. The third of these options is particularly attractive, as it obviates the need to measure the speed of sound in the measured fluid as required by the firm two methods. A scheme applying this third option is shown in Figure 16.14. This also multiple test the transmitting and receiving functions so that only one ultrasonic element is needed in each transducer. The forward and backward transit times across the pipe, T_f and $T_{\rm in}$ are given by





$$T_f = \frac{L}{c + v \cos(\theta)} \quad ; \quad T_b = \frac{L}{c - v \cos(\theta)}$$

where c is the velocity of sound in the fluid, v is the flow velocity, L is the distance between the ultrasonic transmitter and receiver, and θ is the angle of the ultrasonic beam with respect to the fluid flow axis.

The time difference, δT , is given by

$$\delta T = T_b - T_f = \frac{2\nu L\cos(\theta)}{c^2 - \nu^2\cos^2(\theta)}.$$

This requires knowledge of c before it can be solved. However, a solution can be found much more simply if the receipt of a pulse is used to trigger transmission of the next ultrasonic energy pulse. Then, the frequencies of the forward and backward pulse trains are given by

$$F_{I} = \frac{1}{T_{f}} = \frac{c - v \cos(\theta)}{L} \quad ; \quad F_{b} = \frac{1}{T_{b}} = \frac{c + v \cos(\theta)}{L}$$

If the two frequency signals are now multiplied together, the resulting beat frequency is given by

$$\delta F = F_k - F_f = \frac{2\nu\cos(\theta)}{L}$$

c has now been eliminated, and v can be calculated from a measurement of &F as

$$v = \frac{L\delta F}{2\cos(\theta)}$$

This is often known as the sing-around flowmeter.

Transit time flowmeters are of more general use than Doppler shift flowmeters, particularly where the pipe diameter involved is large and hence the transit time is consequently sufficiently large to be measured with reasonable accuracy. It is possible then to reduce the inaccuracy value down to $\pm 0.5\%$. However, the instrument costs more than a Doppler shift flowmeter because of the greater complexity of the electronics needed to make accurate transit time measurements.

Combined Doppler shift/transit time flowmeters

Recently, some manufacturers have developed ultrasonic flowmeters that use a combination of Doppler shift and transit time. The exact mechanism by which these work is rarely, if ever, disclosed, as manufacturers wish to protect details from competitors. However, details of various forms of combined Doppler shift/transit time measurement techniques are filed in patent offices.

16.3.8 Other Types of Flowmsters for Mossuring Volume Flow Rate

Gene-type meter

A gate meter consists of a spring-loaded, hiaged flap mounted at right angles to the direction of fluid flow in the fluid-carrying pipe. The flap is connected to a pointer outside the pipe, The fluid flow deflects the flap and pointer, and the flow rate is indicated by a graduated scale behind the pointer. The major difficulty with such devices is in preventing leaks at the hinge point. A variation on this principle is the *air vane meter*, which measures deflection of the flap by a potentiometer inside the pipe. This is used to measure airflow within automotive fuel-injection systems. Another similar device is the *target meter*. This consists of a circular, disc-shaped flap in the pipe. Fluid flow rate is inferred from the force exerted on the disc measured by strain gauges bunded to it. This meter is very useful for measuring the flow of dilute slurries but does not find wide application elnewhere as it has a relatively high cost. Measurement uncertainty in all of these rooms of meters varies between 1 and 5% according to the cost and design of each instrument.

let meter

These come in two forms—a single jet meter and a multiple jet meter. In the first, flow is diverted into a single jet, which impinges on the radial vanes of an impeller. The multiple jet form diverts the flow into multiple jets arranged at equal angles around an impeller mounted on a borizontal axis.

A paddle wheel meter is a variation of the single jet meter in which the impeller only projects penalty into the flowing fluid.

Pallon wheel flowmater

This uses a similar mechanical arrangement to the old-fashioned water wheels used for power generation at the time of the industrial revolution. Flowing fluid is directed onto the blades of the flowmeter wheel by a jet, and the flow rate is determined from the rate of rotation the wheel. This type of the flow rate of a diverse range of the mass. Including acids, agreessive chemicals, and hot fats at both low and high flow rates. Special versions can measure very small flow rates down to 3 ml/min.

Laser Deppler flowmeter

Instrument gives direct measurements of flow velocity for liquids containing suspended the flowing in a pipe. Light from a later is focused by an optical system to a point in the fiber-optic cables being used commonly to transmit the light. The movement of the causes a Doppler shift of the scattered light and produces a signal in a photodetector that related to the fluid velocity. A very wide range of flow velocities between 10 μ m/s and 105 m/s can be measured by this technique.

Because sufficient particles for satisfactory operation are normally present naturally in most liquid and gaseous fluids, the introduction of artificial particles is rarely needed. The technique is advantageous in measuring flow velocity directly rather than inferring it from a pressure difference. It also causes no interruption in the flow and, as the instrument can be made very small, it can measure velocity in confined areas. One limitation is that it measures local flow velocity in the vicinity of the focal point of the light beam, which can lead to large errors in the estimation of mean volume flow rate if the flow profile is not uniform. However, this limitation can be used constructively in applications of the instrument where the flow profile across the cross section of a pipe is determined by measuring the velocity at a succession of points.

The final comment on this instrument has to be that although it could potentially be used in many applications, it has competition from many other types of instruments that offer similar performance at lower cost. Its main application at the present time is in measuring blood flow in medical applications.

Thermal anemometers

Thermal anemometry was first used in a hot-wire anemometer to measure the volume flow rate of gases flowing ia pipes. A hot-wire anemometer consists of a piece of thin (typical diameter 5 μ m), electrically heated wire (usually tungsten, platinum of a platinum-iridium alloy) inserted into the gas flow. The flowing gas has a cooling effect on the wire, which reduces its resistance. Measurement of the resistance change (usually by a bridge circuit) allows the volume flow rate of the gas to be calculated. Unfortunately, the device is not robust because of the very small diameter of the wire used in its construction. However, it has a very fast speed of response, which makes it as ideal measurement device in conditions where the flow velocity is changing. It is also insensitive to the direction of gas flow, making it a very useful measuring device in conditions of turbulent flow. Recently, more robust devices have been made by using a thin metal film instead of a wire. In this form, the device is known as a hot-film anemometer. Typically, the film is platinum and is deposited on a quartz probe of a typical diameter of 0.05 mm. The increased robustness means that the hot-film anemometer is also used to measure the flow rate of liquids such as water.

Coriolis meter

While the Coriolis meter is intended primarily to be a mass flow-measuring instrument, it can also be used to measure volume flow rate when high measurement accuracy is required. However, its high cost means that alternative instruments are normally used for measuring volume flow rate.

16.3.9 Open Channel Flewmeters

Open channel flowmeters measure the flow of liquids in open channels and are particularly elevant to measuring the flow of water in rivers as part of environmental management hemes. The normal procedure is to build a weir or flume of constant width across the flow and measure the velocity of flow and the height of liquid immediately before the weir or flume with an ultrasonic or radar level sensor, as shown in Figure 16.15. The volume flow rate can then be calculated from this measured height.

As an alternative to building a weir or flume, electromagnetic flowmeters up to 180 mm wide are available that can be placed across the channel to measure the flow velocity, providing the flowing liquid is conductive. If the channel is wider than 180 mm, two or more electromagnetic meters can be placed side by side. Apart from measuring the flow velocity in this way, the height of the flowing liquid must also be measured, and the width of the channel must also be known in order to calculate the volume flow rate.

As a third alternative, ultrasonic flowmeters are also used to measure flow velocity in conjunction with a device to measure the liquid depth.

16.4 Intelligent Flowmeters

All the usual benefits associated with intelligent instruments are applicable to most types of flowmeters. Indeed, all types of mass flowneters routinely have intelligence as an integral part of the instrument. For volume flow rate measurement, intelligent differential pressuremeasuring instruments can be used to good effect in conjunction with obstruction-type flow



transducers. One immediate benefit of this in the case of the commonest flow restriction device, the orifice plate, is to extend the lowest flow measurable with acceptable accuracy down to 20%of the maximum flow value. In positive displacement meters, intelligence allows compensation for thermal expansion of meter components and temperature-induced viscosity changes. Correction for variations in flow pressure is also provided for. Intelligent electromagnetic flowmeters are also available, and these have a self-diagnosis and self-adjustment capability. The usable instrument range is typically from 3 to 100% of the full-scale reading, and the quoted maximum inaccuracy is $\pm 0.5\%$. It is also normal to include a nonvolatile memory to protect constants used for correcting for modifying inputs and no on against power supply failures. Intelligent turbine meters are able to detect their own bearing wear and also report deviations from initial calibration due to blade damage, etc. Some versions also have a self-adjustment capability.

The ability to carry out digital signal processing has also led to emergence of the cross-correlation ultrasonic flowmeter. This is a variant of the transit time form of ultrasonic flowmeter in which a series of ultrasonic signals are injected into the flowing liquid. The ultrasonic receiver stores the echo pattern from each input signal and then cross-correlation techniques are used to produce a map of the profile of the water flow in different layers. Thus, the instrument provides information on the profile of the flow rate across the cross section of the pipe rather than just giving a measurement of the mean flow rate in the pipe.

The trend is now moving toward total flow computers, which can process inputs from almost any type of transducer. Such devices allow user input of parameters such as specific gravity, fluid density, viacosity, pipe diameters, thermal expansion coefficients, and discharge coefficients. Auxiliary inputs from temperature transducers are also catered for. After processing raw flow transducer output with this additional data, flow computers are able to produce measurements of flow to a very high degree of accuracy.

16.5 Choice between Flowmeters for Particular Applications

The number of relevant factors to be considered when specifying a flowmeter for a particular application is very large. These include the temperature and pressure of the fluid, its density, viscosity, chemical properties and abrasiveness, whether it contains particles, whether it is a liquid or gas, etc. This narrows the field to a subset of instruments that are physically capable of making the measurement. Next, the required performance factors of accuracy, rangeability, acceptable pressure drop, output signal characteristics, reliability, and service life must be considered. Accuracy requirements vary widely across different applications, with measurement uncertainty of \pm 5% being acceptable in some and less than \pm 0.5% being demanded in other-Finally, economic viability must be assessed, which must take into account not only the purchase cost, but also reliability, installation difficulties, maintenance requirements, and service life.

only a visual indication of flow rate is needed, the variable area meter is popular. Where a flow sussurement in the form of an electrical signal is required, the choice of available arouments is very large. The orifice plate is used extremely commonly for such purposes and course for almost 50% of instruments currently in use in industry. Other forms of differential resure meters and electromagnetic flowmeters are used in significant numbers. Currently, there is a trend away from rotating devices, such as turbine meters and positive displacement meters. At the same time, usage of ultrasonic and vortex meters is expanding.

16.6 Calibration of Flowmeters

The first consideration in choosing a suitable way to calibrate flow-measuring instruments is to establish exactly what accuracy level is needed so that the calibration system instituted does not cost more than necessary. In some cases, such as handling valuable fluids or where there are legal inquirements as in petrol pumps, high accuracy levels (e.g., error $\leq 0.1\%$) are necessary and the expensive procedures necessary to achieve these levels are justified. However, in other situations, such as in measuring additives to the main stream in a process plant, only low levels of accuracy are needed (e.g., error $\approx 5\%$ is acceptable) and relatively inexpensive calibration procedures are inficient.

The accuracy of flow measurement is affected greatly by the flow conditions and characteristics of the flowing fluid. Therefore, wherever possible, process flow-measuring instruments are alibrated on-site in their normal measuring position. This ensures that calibration is performed in the actual flow conditions, which are difficult or impossible to reproduce exactly in a liboratory. To ensure the validity of such calibration, it is also normal practice to repeat flow calibration checks until the same reading is obtained in two consecutive tests. However, it has been suggested that even these preclassions are inadequate and that statistical procedures are needed.

If on-site calibration is not feasible or is not accurate enough, the only alternative is to send the instrument away for calibration using special equipment provided by instrument manufacturers or other specialist calibration companies. However, this is usually an expensive option. Furthermore, the calibration facility does not replicate the normal operating conditions of the meter tested, and appropriate companiation for differences between calibration conditions and normal use conditions must be applied.

The equipment and procedures used for calibration depend on whether mass, liquid, or Gaseous flows are being measured. Therefore, separate sections are devoted to each of these Gases. It must also be stressed that all calibration procedures mestioned in the following paragraphs in respect to fluid flow only refer to flows of single phase fluids (i.e., liquids or gases). Where a second or third phase is present, calibration is much more difficult and specialist advice mould be sought from the manufacturer of the instrument used for measurement.

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16.6.1 Calibration Equipment and Procedures for Mass Flew-Measuring Instruments

Where the conveyor method is used for measuring the mass flow of solids in the form of particles or powders, both mass-measuring and velocity-measuring instruments are involved. Suitable calibration techniques for each of these are discussed in later chapters.

In the case of Coriolis and thermal mass flowmeters, the usual method of calibrating these while in situ in their normal measurement position is to provide a diversion valve after the meter During calibration procedures, the valve is opened for a measured time period to allow some of the fluid to flow into a container that is subsequently weighed. Alternatively, the meter can be removed for calibration using special test rigs normally provided by the instrument manufacturer.

16.6.2 Calibration Equipment and Procedures for Instruments Measuring Volume Flow Rate of Liquids

Calibrated tank

Probably the simplest piece of equipment available for calibrating instruments measuring liquid flow rates is the calibrated tank. This consists of a cylindrical vessel, as shown in Figure 16.16, with conical ends that facilitate draining and cleaning of the tank. A *sight rube* with a graduated scale is placed alongside the final, upper, cylindrical part of the tank, which allows the volume of liquid in the tank to be measured accurately. Flow rate calibration is performed by measuring the time taken, starting from an empty tank, for a given volume of liquid to flow into the vessel.

Because the calibration procedure starts and ends in zero flow conditions, it is not suitable for calibrating instruments affected by flow acceleration and deceleration characteristics. This therefore excludes instruments such as differential pressure meters (orifice plate, flow nozzle. Venturi, Dall flow tube, pitot tube), turbine flowmeters, and vortex-shedding flowmeters. The technique is further limited to the calibration of low-viscosity liquid flows, although lining the tank with an epoxy coating can allow the system to cope with somewhat higher viscosities. The limiting factor is this case is the drainage characteristics of the tank, which must be such that the residue liquid left after draining has an insufficient volume to affect the accuracy of the next calibration.

Pipe prever

The commonest form of pipe prover is the bidirectional type, shown in Figure 16.17, which consists of a U-shaped tube of metal of accurately known cross section. The purpose of the U bend is to give a long flow path within a compact spatial volume. Alternative varions with more than one U bend also exist to cater for situations where as even longer flow path is required. Inside the tube is a hollow, inflatable sphere, which is filled with water antil its diameter is about 2% larger than that of the tube. As such, the sphere forms a seal with the sides



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of the tube and acts as a piston. The prover is connected into the existing fluid-carrying pipe network via tappings either side of a bypass valve. A four-way valve at the start of the U tube allows fluid to be directed in either direction around it. Calibration is performed by diverting flow into the prover and measuring the time taken for the sphere to travel between twodetectors in the tube. The detectors are normally of an electromechanical, plunger type

Unidirectional versions of the aforementioned also exist is which fluid only flows in one direction around the table. A special handling valve has to be provided to return the sphere to the starting point after each calibration, but the absence of a four-way flow control valve makes such devices significantly less expensive than bidirectional types.

Pipe provers are particularly suited to the calibration of pressure-measuring instruments that have a pulse type of output, such as turbine meters. In such cases, the detector switches in the tube can be made to gate the instrument's output pulse counter. This enables not only the basic instrument to be calibrated, but also the ancillary electronics within it at the same time. The inaccuracy level of such provers can be as low as $\pm 0.1\%$. This level of accuracy is maintained for high fluid viscosity levels and also at very high flow rates. Even higher accuracy is provided by an alternative form of prover, which consists of a long, straight metal tube containing a metal piston. However, such devices are more expensive than the other types discussed earlier and their large space requirements also often cause great difficulties.

Compact prover

The compact prover has an identical operating principle to that of the other pipe provers described earlier but occupies a much smaller spatial volume. It is therefore used extensively in situations where there is insufficient room to use a larger prover. Many different designs of compact prover exist, operating in both unidirectional and bidirectional modes, and one such design is shown in Figure 16.18. Common features of compact provers are an accurately



ined cylinder containing a metal piston that is driven between two reference marks the flowing fluid. The instants at which the reference marks are passed are detected by itches. of optical form in the case of the version shown in Figure 16.18. Provision has to be made within these instruments for returning the piston back to the starting point after each calibration and a hydraulic system is used commonly for this. Again, measuring the piston reverse time is made easier if the switches can be made to gate a pulse train, and therefore compact provers are also most suited to instruments having a pulse-type output such as turbine meters. Measurement uncertainty levels down to $\pm 0.1\%$ are possible.

The main technical difficulty in compact provers is measuring the traverse time, which can be as small as 1 second. The pulse count from a turbine meter in this time would typically be only about 100, making the possible measurement error 1%. To overcome this problem, electronic pulse interpolation techniques have been developed that can count fractions of pulses.

Positive displacement meter

Bigh-quality versions of the positive displacement flowmeter can be used as a reference randard in flowmeter calibration. The general principles of these were explained in Section 16.3.3, Such devices can give measurement inaccuracy levels down to ± 0.25 .

Gravimetric method

A variation on the principle of measuring the volume of liquid flowing is a given time is to weigh the quantity of fluid flowing in a given time. Apart from its applicability to a wider range of instruments, this technique is not limited to low-viscosity fluids, as any residual fluid in the tank before calibration will be detected by the load cells and therefore compensated for. In the implest implementation of this system, fluid is allowed to flow for a measured length of time into a tank resting on load cells. As before, the stop-start mode of fluid flow makes this method insuitable for calibrating differential pressare, turbine, and vortex-shedding flowmeters. It is also unsuitable for measuring high flow rates because of the difficulty in bringing the fluid to rest. These restrictions can be overcome by directing the flowing fluid into the tank via diverser valves. In this alternative, it is important that the timing system be synchronized carefully with peration of the diverter valves.

All versions of gravimetric calibration equipment are less robust than volumetric types and so masite use is not recommended.

Onfice plate

A flow line equipped with a certified orifice plate is sometimes used as a reference standard m flow calibration, especially for high flow rates through large-bore pipes. While measurement internatinty is of the order of $\pm 1\%$ at best, this is adequate for calibrating many flow-measuring internation.

Turbine meter

Turbine meters are also used as a reference standard for testing flowmeters. Their main application, as for ordice plates, is in calibrating high flow rates through large-bore pipes. Measurement uncertainty down to $\pm 0.2\%$ is attainable.

16.6.3 Calibration Equipment and Procedures for Instruments Measuring Volume Flow Rate of Gases

Calibration of gaseous flows poses considerable difficulties compared with calibrating liquid flows. These problems include the lower density of gases, their compressibility, and difficulty in establishing a suitable liquid/air interface as utilized in many liquid flow measurement systems.

In consequence, the main methods of calibrating gaseous flows, as described later, are small in number. Certain other specialized techniques, including the gravimetric method and the pressure-volume-temperature method, are also available. These provide primary reference standards for gaseous flow calibration with measurement uncertainty down to $\pm 0.3\%$. However, the expense of the equipment involved is such that it is usually only available in National Standards Laboratories.

Bell prover

A bell prover consists of a hollow, inverted, metal cylinder suspended over a bath containing light oil, as shown in Figure 16.19. The air volume in the cylinder above the oil is connected, via a tube and a valve, to the flowmeter being calibrated. An air flow through the meter is created by allowing the cylinder to fall downward into the bath, thus displacing the air contained within it. The flow rate, which is measured by timing the rate of fall of the cylinder, can be adjusted by changing the value of counterweights attached via a low-friction pulley system to the cylinder. This is essentially laboratory-only equipment and therefore on-size calibration is not possible.

Positive displacement meter

As for liquid flow calibration, positive displacement flowmeters can be used for the calibration of gaseous flows with inaccuracy levels down to $\pm 0.2\%$.

Compact prover

Compact provers of the type used for calibrating liquid flows are unsuitable for application to gaseous flows. However, special designs of compact provers are being developed for gaseous flows, and hence such devices may find application in gaseous flow calibration in the future.





16.6.4 Reference Standards

Traceability of flow rate calibration to fundamental standards is provided for by reference to primary standards of the separate quantities that the flow rate is calculated from. Mass the summary standards of the separate quantities that the flow rate is calculated from. Mass the summary standard for the separate quantities that the flow rate is calculated from. Mass the summary standard by comparison with a copy of the international standard kilogram the chapter 18), and time is calibrated by reference to a caesium resonator standard. Volume the standard reference volumes that are themselves calibrated promotically using a mass measurement system traceable to the standard kilogram.

16.7 Summary

We started this chapter off by observing that flow rate could be measured either as mass flow rate or volume flow rate. We also observed that the material being measured could be in solid, inquid, or gaseous form. In the case of solids, we quickly found that this could only be measured in terms of the mass flow rate. However, in the case of liquids and gases, we found that we have

the option of measuring either mass flow rate or volume flow rate. Of these two alternatives, we observed that mass flow measurement was the more accurate.

Before proceeding to look at flow measurement in detail, we had a brief look at the differences between laminar flow and turbulent flow. This taught us that the flow rate was difficult to measure in turbulent flow conditions and even in laminar flow at high velocities. Therefore, as far as possible, the measurement was made at a point in the flow where the flow was at least approximately laminar and the flow velocity was as small as possible.

This allowed us to look at flow-measuring instruments in more detail. We started with mass flow and observed that this could be measured in one of three ways—conveyor-based methods, Coriolis flowmeter, and thermal mass flowmeter. We examined the mode of operation of each of these and made some comments about their applicability.

Moving on, we then started to look at volume flow rate measurement and worked progressively through a large number of different instruments that can be used. First, we looked at obstruction devices. These are placed in a fluid-carrying pipe and cause a pressure difference across the obstruction that is a function of the flow rate of the fluid. Various obstruction devices were discussed, from the commonly used inexpensive but less accurate orifice plate to more expensive but more accurate devices such as the Venturi tube, flow nozzle, and Dall flow tube

After looking at flow obstruction devices, we looked at a number of other instruments for measuring volume flow rate of fluids flowing in pipes, including the variable area flowmeter, positive displacement flowmeter, turbine flowmeter, electromagnetic flowmeter, vortex-shedding flowmeter, and, finally, ultranonic flowmeters in both transit time and Doppler shift forms. We also looked briefly at several other devices, including gate-type meters, laser Doppler flowmeter, and thermal anenometer. Finally, we also had a brief look at measuring fluid flow in open channels and observed three ways of doing this.

We rounded off our discussion of flow measurement by looking at intelligent devices. We observed that these bring the usual benefits associated with intelligent instruments, including improved measurement accuracy and extended measurement range, with facilities for self-diagnosis and self-adjustment also being common. This led on to some discussion about the most appropriate instrument to use in particular flow measurement situations and applications out of all the instruments covered in the chapter.

We then concluded the chapter by considering the subject of flowmeter calibration. These calibration methods were considered in three parts. First, we looked at the calibration of instruments measuring mass flow. Second, we looked at the calibration of instruments measuring the volume flow rate of liquids. Finally, we looked at the calibration of instruments measuring the volume flow rate of gases.

16.8 Problems

- 16.1. Name and discuss three different kinds of instruments used for measuring the mass flow rate of substances (mass flowing in unit time).
- 16.2. Instruments used to measure the volume flow rate of fluids (volume flowing in unit time) can be divided into a number of different types. Explain what these different types are and discuss briefly how instruments in each class work, using sketches of instruments as appropriate.
- 16.3. What is a Coriolis meter? What is it used for and how does it work?
- 16.4. Name four different kinds of differential pressure meters. Discuss briefly how each one works and explain the main advantages and disadvantages of each type.
- 16.5. Explain how each of the following works and give typical applications: rotameter and rotary piston meter.
- 16.6. How does an electromagnetic flowmeter work and what is it typically used for?
- 16.7. Discuss the mode of operation and applications of each of the following: turbine meter and vostex-shedding flowmeter.
- 16.8. What are the two main types of ultrasonic flowmeters? Discuss the mode of operation of each.
- 16.9. How do each of the following work and what are they particularly useful for: gate-type meter, jet meter. Pelton wheel meter, later Doppler flow meter, and thermal anencometer.
- 16.10. What is an open channel flowmaster? Draw a sketch of one and explain how it works.
- 16.11. What lastruments, special equipment, and procedures are used in the calibration of flowmeters used for measuring the flow of liquids?
- 16.12. What instruments, special equipment, and procedures are used in the calibration of flowmeters used for measuring the flow of gases?

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CHAPTER I Z

Level Measurement

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17.1 Introduction

17.14 Problems 475

Level transverement is required in a wide range of applications and can involve the measurement of solids in the form of powders or small particles as well as liquids. While some applications require levels to be measured to a high degree of accuracy, other applications only need an approximate indication of level. A wide variety of instruments are available to meet these differing meds.

All or these devices are discussed in more detail in this chepter.

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17.2 Dipsticks

Dipsticks offer a simple means of measuring the level of liquids approximately. The ordinar dipstick is the least expensive device available. This consists of a metal bar on which a scale is etched, as shown in Figure 17.1a. The bar is fixed at a known position in the liquid containing vessel. A level measurement is made by removing the instrument from the vessel and reading off how far up the scale the liquid has wetted. As a human operator is required to remove and read the dipstick, this method can only be used in relatively small and shallow vessels. One common use is in checking the remaining amount of beer in an alc cask.

The optical dipstick, illustrated in Figure 17.1b, is an alternative form that allows a reading to be obtained without removing the dipstick from the vessel and so is applicable to larger, deeper tanks. Light from a source is reflected from a mirror, passes round the chamfered end of the dipstick, and enters a light detector after reflection by a second mirror. When the chamfered end comes into contact with liquid, its internal reflection properties are altered and light no longer enters the detector. By using a suitable mechanical drive system to move the tastrument up and down and measure its position, the liquid level can be monitored.

17.3 Float Systems

Float systems are simple and inexpensive and provide an alternative way of measuring the level of liquids approximately that is widely used. The system consists of a float on the surface of the liquid whose position is measured by means of a suitable transducer. They have a typical measurement inaccuracy of $\pm 1\%$. The system using a potentiometer, shown earlier in Figure 2.2, is very common and is well known for its application to monitoring the level in



Dipsticles: (a) simple and (b) optical.

which fuel tasks. An alternative system, which is used in greater numbers, is called the Rost-sad-tape pauge (or tank gauge). This has a tape attached to the float that passes round a need vertically above the float. The other end of the tape is attached to either a connecticity or a negative-rate counterspring. The amount of rotation of the pulley, measured invester a synchro or a potentiometer, is then proportional to the liquid level. These two constituty mechanical systems of measurement are popular in many applications, but the sumance requirements of them are always high.

17. Prossure-Measuring Devices (Hydrostatic Systems)

Pressure-measuring devices measure the liquid level to a better accuracy and use the principle that the hydrometic pressure due to a liquid is directly proportional to its depth and hence to the level of its surface. Several instruments are available that use this principle and are widely used in many industries, particularly in harsh chemical environments. In the case of open-topped vessels for covered ones that are vented to the atmosphere), the level can be measured by inserting a pressure sensor at the bottom of the vessel, as shown in Figure 17.2a. The liquid level, k, is then related to the measured pressure, P, according to $h = P/\rho_R$, where ρ is the liquid density and r is



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acceleration due to gravity. One source of error in this method can be imprecise knowledge of the liquid density. This can be a particular problem in the case of liquid solutions and mixtures (especially hydrocarbons), and in some cases only an estimate of density is available. Even with single liquids, the density is subject to variation with temperature, and therefore temperature measurement may be required if very accurate level measurements are needed.

Where liquid-containing vessels are totally sealed, the liquid level can be calculated by measuring the differential pressure between the top and the bottom of the tank, as shown in Figure 17.2h. The differential pressure transducer used is normally a standard diaphragm type, although siliconbased microsensors are being used in increasing numbers. The fiquid level is related to the differential pressure measured, δP , according to $h = \delta P/\rho g$. The same comments as for the case of the open vessel apply regarding uncertainty in the value of ρ . An additional problem that can occur is an accumulation of liquid on the side of the differential pressure transducer measuring the pressure at the top of the vessel. This can arise because of temperature fluctuations, which allow liquid to alternately vaporize from the liquid surface and then condense in the pressure tapping at the top of the vessel. The effect of this on the accuracy of the differential pressure measurement is severe, but the problem is avoided easily by placing a drain pot in the system

A final pressure-related system of level measurement is the *bubbler unit* shown in Figure 17.2c. This uses a dip pipe that reaches to the bottom of the tank and is purged free of liquid by a steady flow of gas through it. The rate of flow is adjusted until gas bubbles are just seen to emerge from the end of the tube. The pressure in the tube, measured by a pressure transducer, is then equal to the liquid pressure at the bottom of the tank. It is important that the gas used is inert with respect to the liquid in the vessel. Nitrogen, or sometimes just air, is suitable in most cases. Gas consumption is low, and a cylinder of nitrogen may typically last 6 months. This method is suitable for measuring the liquid pressure at the bottom of both open and sealed tanks. It is particularly advastageous in avoiding the large maintenance problem associated with leaks at the bottom of tanks at the site of pressure tappings required by alternative methods.

Measurement uncertainty varies according to the application and condition of the measured material. A typical value would be $\pm 0.5\%$ of full-scale reading, although $\pm 0.1\%$ can be achieved in some circumstances.

17.5 Capacitive Devices

Capacitive devices are widely used for measuring the level of both liquids and solids in powdered or granular form. They perform well in many applications, but become inaccurate if the measured substance is prone to contamination by agents that change the dielectric constant. Ingress of moisture into powders is one such example of this. They are also suitable for use in extreme conditions measuring liquid metals (high temperatures), liquid gates (low temperatures), corrosive liquids (acids, etc.), and high-pressure processes. Two versions are



used according to whether the measured substance is conducting or not. For nonconducting substances (less than 0.1 µmho/cm³), two bare-metal capacitor plates in the form of concentric cylinders are immersed in the substance, as shown in Figure 17.3. The substance behaves as a dielectric between the plates according to the depth of the substance. For concentric cylinder plates of radius *a* and *b* (*b* > *a*), and total height *L*, the depth of the substance, *h*, is related to the measured capacitance, *C*, by

$$h = \frac{C \log_{\sigma}(b/a) - 2\pi\epsilon_{\sigma}}{2\pi\epsilon_{\sigma}(\epsilon - 1)}$$
(17.1)

where ϵ is the relative permittivity of the measured substance and ϵ_{μ} is the permittivity of free space. In the case of conducting substances, exactly the same measurement techniques are applied, but the capacitor plates are encapsulated in an insulating material. The relationship between C and h in Equation (17.1) then has to be modified to allow for the dielectric effect of the insulator. Measurement uncertainty is typically 1-2%,

17.6 Ultrasonic Level Gauge

Ultrasonic level measurement is one of a number of noncontact techniques available. It is used primarily to measure the level of materials that are either in a highly viscous liquid form or in solid (powder or granular) form. The principle of the ultrasonic level gauge is that energy 466 Chepter 17



Ultrasonic level gauge.

from an ultrasonic source above the material is reflected back from the material surface into an ultrasonic energy detector, as illustrated in Figure 17.4. Measurement of the time of flight allows the level of the material surface to be inferred. In alternative versions (only valid for liquids), the ultrasonic source is placed at the bottom of the vessel containing the liquid, and the time of flight between emission, reflection off the liquid surface, and detection back at the bottom of the vessel is measured.

Ultrasonic techniques are especially useful in measuring the position of the interface between two immiscible liquids contained in the same vessel or measuring the sludge or precipitate level at the bottom of a liquid-filled tank. In either case, the method employed is to fix the ultrasonic transmitter-receiver transducer at a known height in the upper liquid, as shown in Figure 17.5. This establishes the level of the liquid/liquid or liquid/sludge level in absolute terms. When using ultrasonic instruments, it is essential that proper compensation is made for the working temperature if this differs from the calibration temperature, as the speed of ultrasound through air varies with temperature (see Chapter 13). Ultrasound speed also has a small sensitivity to humidity, air pressure, and carbon dioxide concentration, but these factors are usually insignificant. Temperature compensation can be achieved in two ways. First, the operating temperature can be measured and an appropriate correction made. Second, and preferably, a comparison method can be used in which the system is calibrated each time it is used by measuring the transit time of ultrasonic energy between two known reference points. This





Measuring interface positions: (a) liquid/liquid interface and (b) liquid/precipitate interface.

second method takes account of humidity, pressure, and carbon dioxide concentration variations as well as providing temperature compensation. With appropriate care, measurement uncertainty can be reduced to about $\pm 1\%$.

17.7 Radar (Microwave) Sensors

Level-measuring instruments using microwave radar are an alternative technique for moncontact measurement. Currently, they are still very expensive (=\$5000), but prices are falling and usage is expanding rapidly. They are able to provide successful level measurement in applications that are otherwise very difficult, such as measurement in closed tanks, where the liquid is turbulent, and in the presence of obstructions and steam condensate. They can also be used for detecting the surface of solids in powder or particulate form. The technique involves directing a constant amplitude, frequency-modulated raicrowave signal at the liquid surface. A receiver measures the phase difference between the reflected signal and the original signal transmitted directly through air to it, as shown in Figure 17.6. This measured phase difference is linearly proportional to the liquid level. The system is similar in principle to altranomic level measurement, but has the important advantage that the transmission time of radar through air is almost totally unaffected by ambient temperature and pressure fluctuations. However, as the microwave frequency is within the band used for radio communications, strict conditions on amplitude levels have to be mitsfied, and the appropriate licenses have to be obtained.



17.8 Nucleonic (or Radiometric) Sensors

Nucleonic, sometimes called radiometric, sensors are relatively expensive. They use a radiation source and detector system located outside a tank is the manner shown in Figure 17.7. The noninvasive nature of this technique in using a source and detector system outside the tank is particularly attractive. The absorption of both β and γ rays varies with the amount of material between the source and the detector, and hence is a function of the level of the material in the tank. Caesium-137 is a commonly used γ -ray source. The radiation level measured by the detector, *I*, is related to the length of material in the path, *x*, according to

$$I = I_{\rho} \exp\left(-\mu \rho x\right), \tag{17.2}$$

where l_{ρ} is the intensity of radiation that would be received by the detector in the absence of any material, μ is the mass absorption coefficient for the measured material, and ρ is the mass density of the measured material.

In the arrangement shown in Figure 17.7, radiation follows a diagonal path across the material, and therefore some trigonometrical manipulation has to be carried out to determine material level h from x. In some applications, the radiation source can be located in the center of the bottom of the tank, with the detector vertically above it. Where this is possible, the relationship between radiation detected and material level is obtained by directly substituting h in place of x in Equation (17.2). Apart from use with liquid materials at normal



Using a radiation source to measure the level.

temperatures, this method is used commonly for measuring the level of hot, liquid metals and also solid materials in a powdered granular form.

Unfortunately, because of the obvious dangers associated with using radiation sources, very strict safety regulations have to be satisfied when applying this technique. Very low activity radiation sources are used in some systems to overcome safety problems, but the system is then sensitive to background radiation and special precautions have to be taken regarding the provision of adequate shielding. Because of the many difficulties in using this technique, it is only used in special applications.

17.9 Other Techniques

17.9.1 Vibrating Level Sensor

The principle of the vibrating level sensor is illustrated in Figure 17.8. The instrument consists of two piezoelectric oscillators fixed to the inside of a hollow tube that generate flexural vibrations in the tube at its resonant frequency. The resonant frequency of the tube varies according to the depth of its immersion in the liquid. A phase-locked loop circuit is used to track these changes in resonant frequency and adjust the excitation frequency applied to the tube by the piezoelectric oscillators. The liquid level measurement is therefore obtained in terms of the output frequency of the oscillator when the tube is resonanting.



17.9.2 Laser Methods

One laser-based method is the *reflective level sensor*. This sensor uses light from a laser source that is reflected off the surface of the measured liquid into a line array of charge-coupled devices, as shown in Figure 17.9. Only one of these will sense light, according to the level of the liquid. An alternative, laser-based technique operates on the same general principles as the radar method described earlier but uses laser-generated pulses of infrared light directed at the liquid surface. This is immune to environmental conditions and can be used with nealed vessels, provided that a glass window is at the top of the vessel.

17.10 Intelligent Level-Measuring Instruments

Most types of level gauges are now available in intelligent form. Pressure-measuring devices (Section 17.3) are obvious candidates for inclusion within intelligent level-measuring instruments, and versions claiming $\pm 0.05\%$ inaccuracy are now on the market. Such instruments can also carry out additional functions, such as providing automatic compensation for liquid density variations. Microprocessors are also used to simplify installation and setup procedures.

17.11 Choice between Different Level Sensors

The first consideration in choosing a level sensor is whether it is a liquid or a solid that is being measured. The second consideration is the degree of measurement accuracy required.

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Figure 17.9 Reflective level sensor

If it is liquids being measured and a relatively low level of accuracy is acceptable, dipsticks and float systems would often be used. Of these, dipsticks require a human operator, whereas float systems provide an electrical output that can be recorded or output to an electronic display as required.

Where greater measurement accuracy is required in the measurement of liquid level, a number of different devices can be used. These can be divided into two distinct classes. according to whether the instrument does or does not make contact with the material whose level is being measured. The advantage of noncontact devices is that they have a higher reliability than contact devices for a number of reasons. All pressure-measuring devices (hydrostatic systems) fall into the class of a device that does make contact with the measured liquid and are used quite frequently. However, if there is a particular need for high reliability, noncontact devices such as capacitive, ultrasonic, or radiation devices are preferred. Of these, capacitive sensors are used most commonly but are insuitable for applications where the liquid may become contaminated, as this changes its dielectric constant and hence the capacitance value. Ultrasonic sensors are less affected by contamination of the measured fluid but only work well with highly viscous fluids. Rader (microwave) and radiation sensors have the best immunity to changes in temperature. composition, moisture content, and density of the measured material and so are preferred in many applications. However, both of these are relatively expensive. Purther guidance on this can be found in elsewhere.
In the case of measuring the level of solids (which must be is powdered or particle form), the choice of instrument is limited to the options of capacitive, ultrasonic, radar (microwave), and radiation sensors. As for measuring the level of liquids, radar and radiation sensors have the best immunity to changes in temperature, composition, moisture content, and density of the measured material and so are preferred in many applications. However, they both have a high cost. Either capacitive or ultrasonic devices provide a less expensive solution. Capacitive devices generally perform better but become inaccurate if the measured material is contaminated, in which case ultrasonic sensors are preferred out of these two less expensive solutions.

17.12 Calibration of Level Sensors

The sophistication of calibration procedures for level sensors depends on the degree of accuracy required. If the accuracy demands are not too high and a tank is relatively shallow, simple dipatick inserted into a tank will suffice to verify the output reading of any other form of level sensor being used for monitoring the liquid level in the tank. However, this only provides one calibration point. Other calibration points can only be obtained by putting more liquid into the tank or by emptying some liquid from the tank. Such variation of the liquid level may or may not be convonient. However, even if it can be done without too mach disturbance to normal use of the tank, the reading from the dipstick is of very limited accuracy because of the ambiguity in determining the exact point of contact between the dipstick and the meniscus of the liquid.

If the dipatick method is not accurate enough or is otherwise unsuitable, an alternative method of calibrating the level is to use a calibration tank that has vertical sides and a flat bottom of known cross-sectional area. Tanks with circular bottoms and rectangular bottoms are both used commonly. With the level sensor in situ, measured quantities of liquid are emptied into the tank. This increases the level of liquid is the tank in steps, and each step creates a separate calibration point. The quantity of liquid added at each stage of the calibration process can be measured either in terms of its volume or in terms of its mass. If the volume of each quantity of liquid added is measured, knowledge of the cross-sectional area of the tank bottom allows the liquid level to be calculated directly. If the mass of each quantity of liquid added is measured, the specific gravity of the liquid has to be known in order to calculate its volume and hence the liquid level. In this case, use of water as the calibration liquid is beneficial because its specific gravity is unity and therefore the calculation of level is simplified.

To measure added water in terms of its volume, calibrated volumetric measures are used. If a 1-liter measure is used, this has a typical inaccuracy of $\pm 0.1\%$. Unfortunately, errors in the measurement of each quantity of water added are cumulative, and therefore the possible error after 10 quantities of water have been added increases 10-fold to $\pm 1.0\%$. If 20 quantities are added to create 20 calibration points, the possible error is $\pm 2.0\%$ and so on.

Better necessary can be obtained in the calibration process if the added water is measured in terms of its mass. This can be done conveniently by mounting the calibration tank on an electronic load cell. The typical inaccuracy of such a load cell is $\pm 0.05\%$ of its full-scale reading. This means that the inaccuracy of the level measurement when the tank is full is $\pm 0.05\%$ if the load cell is chosen such that it is giving its maximum output mass reading when the tank is full. Because the total mass of water in the tank is measured at each point in the calibration process, measurement errors are not cumulative. However, errors do increase for smaller volumes of water in the tank because measurement uncertainty is expressed as a percentage of the full-scale reading of the load cell. Therefore, when the tank is only 10% full, the possible measurement error is $\pm 0.5\%$. This means that calibration inaccuracy increases for smaller quantities of water in the tank but measurement uncertainty is always less than the case where measured volumes of water are added to the tank even for low levels.

Wherever possible. Ilquid used in the calibration tank is water, as this avoids the cost involved in using any other liquid and it also makes the calculation of level simpler when the quantities of water added to the tank are measured in terms of their volume. Unfortunately, liquid used in the tank often has to be the same as that which the sensor being calibrated normally measures. For example, the specific gravity of the measured liquid is crucial to the operation of both hydrostatic systems and capacitive level assors. Another example is level measurement using a radiation source, as the passage of radiation through the liquid between the source and the detector is affected by the nature of the liquid.

17.13 Summary

We have seen that level sensors can be used to measure the position of the surface within some type of container of both solid materials in the form of powders and of liquids. We have looked at various types of level sensors, following which we considered how the various forms of level mensors available could be calibrated.

One very important observation made at the start of our discussion was that the accuracy inquirements during level measurement vary widely, which has an important effect on the type of sensor used in any given situation and the corresponding calibration requirements. For example, if the surface level of a liquid within a tank used for cooling purposes in an industrial process is being monitored, only a very approximate measurement of level is needed to allow a prediction about how long it will be before the tank needs refilling. However, if the level of liquid of a consumer product within a container is being monitored during the filling process, high accuracy is required in the measurement process.

Where only approximate measurements of liquid level are needed, we saw that dipaticks provide a suitable, low-cost method of measurement, although these require a human operator and so cannot be used as part of an automatic level control system. Float systems are also

relatively low-continstruments and have an electrical form of output that can be used as part of an automatic level control system, although the accuracy is little better than that of dipaticks.

Our discussion then moved on to sensors that provide greater measurement accuracy. First among these were hydrostatic systems. These are widely used in many industries for measuring the liquid level, particularly in harsh chemical environments. Measurement uncertainty is usually about $\pm 0.5\%$ of full-scale reading, although this can be reduced to $\pm 0.1\%$ in the best hydrostatic systems. Because accurate knowledge of the liquid density is important in the operation of hydrostatic systems, serious measurement errors can occur if these systems are used to measure the level of mixtures of liquids, as the density of such mixtures is rarely known to a sufficient degree of accuracy.

Moving on to look at capacitive level sensors, we observed that these were widely used for measuring the level of both liquids and solids in powdered or granular form, with a typical measurement uncertainty of 1-2%. They are particularly useful for measuring the level of difficult materials such as liquid metals (high temperatures), liquid gases (low temperatures), and corrosive liquids (acids, etc.). However, they become inaccurate if the measured substance is prone to contamination by agents that change the dielectric constant.

Next on the list of devices studied was the ultrasonic level aensor. We noted that this is one of a number of noncontact techniques available. It is used primarily to measure the level of materials that are either in a highly viscous liquid form or in solid (powder or granular) form. We also observed that it is particularly useful for measuring the position of the interface between two immiscible liquids contained in the same vessel, and also for measuring the sludge or precipitate level at the bottom of a liquid-filled tank. The lowest measurement uncertainty achievable is $\pm 1\%$, but errors increase if the system is not calibrated properly, particularly in respect of the ambient temperature because of the changes in ultrasound speed that occur when the temperature changes.

The discussion then moved on to radar sensors, another noncontact measurement technique. We saw that this, albeit very expensive, technique provided a method for measuring the level in conditions that are too difficult for most other forms of level sensors. Such conditions include measurement in closed tanks, where the liquid is turbulent, and in the presence of obstructions and steam condensate. Like ultrasonic sensors, they can also measure the level of actids in powder or granular form.

We then looked at nucleonic sensors. These provide yet another means of noncontact level measurement that finds niche applications is measuring the level of hot, molten metals and also in measuring the level of powdered or grasular solids. However, apart from the high cost of nucleonic sensors, it is necessary to adhere to very strict safety regulations when using such tensors.

Having then looked briefly at two other less common level sensors, namely the vibrating level sensor and laser-based sensors, we went on to make brief comments about intelligent level sensors. We noted that most of the types of level sensors discussed were now available in an intelligent form that quoted measurement uncertainty values down to $\pm 0.05\%$.

The final subject covered in this chapter was that of level sensor calibration. We noted that devices such as a simple dipstick could be used to calibrate neasors that were only required to provide approximate measurements of level. However, for more accurate calibration, we observed that it was usual to use a calibrated tank in which quantities of liquid were added, measured either by weight or by volume, to create a series of calibration points. We concluded that greater accuracy could be achieved in the calibration points if each quantity of liquid was weighed rather than measured with volumetric measures. We also noted that water was the least expensive liquid to use in the calibration tank but observed that it was meessary to use the name liquid as normally measured for certain sensors.

17.14 Problems

- 17.1. How do dipaticks and float systems work and what are their advantages and disadvantages in liquid level measurement?
- 17.2. Sketch three different kinds of hydrostatic level measurement systems. Discuss briefly the mode of operation and applications of each.
- 17.3. Discuss the mode of operation of the following, using a sketch to aid your discussion as appropriate: capacitive level sensor and ultrasonic level sensor.
- 17.4. What are the merits of microwave and radiometric level sensors? Discuss how each of these devices works.
- 17.5. What are the main things to consider when choosing a liquid level sensor for a particular application? What types of devices could you use for an application that required (a) law measurement accuracy, (b) high measurement accuracy where connect between the sensor and the measured liquid is acceptable, or (c) high measurement accuracy where there must not be any contact between the sensor and the measured liquid?
- 17.6. Discuss the range of devices able to measure the level of the surface of solid material is powdered form contained within a hopper.
- 17.7. What procedures could you use to calibrate a sensor that is only required to provide approximate measurements of liquid level?
- 17.8. What is the best calibration procedure to use for sensors required to give high accuracy in level measurement?

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CHAPTER 18

Mass, Force, and Torque Measurement

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18.1 Introduction

Mass, force, and torque are covered together within this chapter because they are closely related quantities. Mass describes the quantity of matter that a body contains. Force is the product of mass times acceleration, according to Newton's second law of motion:

Force = Mass × acceleration.

Forces can be applied in either a horizontal or a vertical direction. A force applied in a downward, vertical direction gives rise to the term *weight*, which is defined as the downward force exerted by a mass subject to a gravitational force:

Weight = Mass × occeleration due to gravity.

The final quantity covered in this chapter, torque, can be regarded as a rotational force. When applied to a body, torque causes the body to rotate about its axis of rotation. This is analogous to the horizontal motion of a body when a horizontal force is applied to it.

18.2 Mass (Weight) Measurement

The mass of a body is always quantified in terms of a measurement of the weight of the body, this being the downward force exerted by the body when it is subject to gravity. Three methods are used to measure this force.

The first method of measuring the downward force exerted by a mass subject to gravity involves the use of a *load cell*. The load cell measures the downward force F, and then the mass M is calculated from the equation:

$$M = F/g$$
.

where g is acceleration due to gravity.

Because the value of g varies by small amounts at different points around the earth's surface, the value of *M* can only be calculated exactly if the value of *g* is known exactly. Nevertheless, load cells are, in fact, the most common instrument used to measure mass, especially in industrial applications. Several different forms of load cells are available. Most load cells are now electronic, although pneumatic and hydraulic types also exist. These types vary in features and accuracy, but all are easy to use as they are deflection-type instruments that give an output reading without operator intervention.

The second method of measuring mass is to use a spring balance. This also measures the downward force when the measured mass is subject to gravity. Hence, as in the case of load cells, the mass value can only be calculated exactly if the value of g is known exactly. Like a load cell, the spring balance is also a deflection-type instrument and so is easy to use.

The final method of measuring mass is to use some form of mass balance instrument. These provide an absolute measurement, as they compare the gravitational force on the mass being measured with the gravitational force on a standard mass. Because the same gravitational force is applied to both masses, the exact value of g is immaterial. However, being a null-type instrument, any form of balance is tedious to use.

The following paragraphs consider these various forms of mass-measuring instruments in more detail.

18.2.1 Electronic Load Coll (Electronic Balance)

The electronic load cell is now the preferred type of load cell in most applications. Within an electronic load cell, the gravitational force on the body being measured is applied to an elastic element. This deflects according to the magnitude of the body mass. Mass measurement is thereby translated into a displacement measurement task.

The elastic elements used are specially shaped and designed, some examples of which are shown in Figure 18.1. The design aims are to obtain a linear output relationship between the applied force and the measured deflection and to make the instrument insensitive to forces that are not applied directly along the sensing axis. Load cells exist in both compression and tension forms. In the compression type, the measured mass is placed on top of a platform resting on the load cell, which therefore compresses the cell. In the alternative tension type, the mass is bung from the load cell, thereby putting the cell into tension.

Various types of displacement transducers are used to measure the deflection of the elastic elements. Of these, the strain gauge is used most commonly, as this gives the best measurement occuracy, with an inaccuracy figure less than $\pm 0.05\%$ of full-scale reading being obtainable. Load cells, including strain gauges, are used to measure masses over a very wide range between 0 and 3000 tonne. The measurement capability of an individual instrument designed to measure masses at the bottom end of this range would typically be 0.1–5 kg, whereas instruments designed for the top of the range would have a typical measurement span of 10–3000 tonne.

Eastic force transducers based on differential transformers (LVDT) to measure delections are used to measure measure up to 25 tonne. Apart from having a lower maximum measuring expediatly, they are also inferior to strain gauge-based instruments in terms of their $\pm 0.2\%$ insecuracy value. Their major advantages are their longevity and almost total lack of maintenance requirements.

The final type of displacement transducer used in this class of instrument is the piezoelectric device. Such instruments are used to measure masses in the range of 0 to 1000 tonne. Piezoelectric Crystals replace the specially designed elastic member used normally in this class of instrument. Allowing the device to be physically small. As discussed previously, such devices can only



measure dynamically changing forces because the output reading results from an induced electrical charge whose magnitude leaks away with time. The fact that the elastic element consists of a piezoelectric crystal means that it is very difficult to design such instruments to be insensitive to forces applied at an angle to the sensing axis. Therefore, special precautions have to be taken in applying these devices. Although such instruments are relatively inexpensive, their lowest inaccuracy is $\pm 1\%$ of fall-scale reading and they also have a high temperature coefficient.

Electronic load cells have significant advantages over most other forms of mass-measuring instruments in terms of their relatively low cost, wide measurement range, tolerance of dusty and corrosive environments, remote measurement capability, tolerance of shock loading, and ease of installation. However, one particular problem that can affect their performance is the phenomenon of creep. Creep describes the permanent deformation that an elastic element undergoes after it has been under load for a period of time. This can lead to significant measurement errors in the form of a bias on all readings if the instrument is not recalibrated.

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Load cell-based electronic balance.

from time to time. However, careful design and choice of materials can largely eliminate the problem.

Several compression-type load cells are often used together in a form of instrument known as an *electronic balance*. This is shown schematically in Figure 18.2. Commonly, either three or four load cells are used in the balance, with the output mass measurement being formed from the sum of the outputs of each cell. Where appropriate, the upper platform can be replaced by a tank for weighing liquids, powders, and so on.

18.2.2 Pneumatic and Hydraulic Load Cells

Pneumatic and hydraulic load cells translate mass measurement into a pressure measurement task, although they are now less common than the electronic load cell. A pneumatic load cell is abown schematically in Figure 18.3. Application of a mass to the cell causes deflection of a



Figure 18.3 Pneumatic load cell.

diaphragm acting as a variable restriction in a nozzle-flapper mechanism. The output pressure measured in the cell is approximately proportional to the magnitude of the gravitational force on the applied mass. The instrument requires a flow of air at its input of around 0.25 m³/h at a pressure of 4 bar. Standard cells are available to measure a wide range of masses. For measurents with a full-scale reading of 25 kg, while instruments with a full-scale reading of 25 kg, while instruments with a full-scale reading of 25 tonne are obtainable at the top of the range. Inaccuracy is typically $\pm 0.5\%$ of full scale in pneumatic load cells.

The alternative, hydraulic load cell is shown in Figure 18.4. In this, the gravitational force due to the unknown mass is applied, via a diaphragm, to oil contained within an enclosed chamber. The corresponding increase in oil pressure is measured by a suitable pressure transducer. These instruments are designed for measuring much larger masses than pneumatic cells, with a load capacity of 500 tonne being common. Special units can be obtained to measure masses as large as 50,000 tonne. In addition to their much greater measuring range, hydraulic load cells are much more accurate than pneumatic cells, with an inaccuracy figure of $\pm 0.05\%$ of full scale being typical. However, in order to obtain such a level of accuracy, correction for the local value of g (acceleration due to gravity) is necessary. A measurement resolution of 0.02% is attainable.

18.2.3 Intelligent Load Cells

Intelligent load cells are formed by adding a microprocessor to a standard cell. This brings no improvement in accuracy because the load cell is already a very accurate device. What it does produce is an intelligent weighing system that can compute total cost from the measured weight, using stored cost per unit weight information, and provide an output in the form of a digital display. Cost per weight values can be prestored for a large number of substances, making such instruments very flexible in their operation.



Figure 18.4 Hydraulic load cell. In applications where the mass of an object is measured by several load cells used together (e.g., load cells located at the corners of a platform in an electronic balance), the total mass can be computed more readily if the individual cells have a microprocessor providing digital output. In addition, it is also possible to use significant differences in the relative readings between different load cells as a fault detection mechanism in the system.

18.2.4 Mass Balance (Weighing) Instruments

Mass balance instruments are based on comparing the gravitational force on the measured mass with the gravitational force on another body of known mass. This principle of mass measurement is known commonly as weighing and is used in instruments such as the beam balance, weigh beam, pendulum scale, and electromagnetic balance. Various forms of mass balance instruments are available, as discussed next.

Beam balance (equal arm balance)

In the beam balance, shown in Figure 18.5, standard masses are added to a pan on one side of a pivoted beam until the magnitude of the gravity force on them balances the magnitude of the gravitational force on the unknown mass acting at the other end of the beam. This equilibrium position is indicated by a pointer that moves against a calibrated scale.

Instruments of this type are capable of measuring a wide span of masses. Those at the top end of the range can typically measure masses up to 1000 grams, whereas those at the bottom end of the range can measure masses of less than 0.01 gram. Measurement resolution can be as good as 1 part in 10^7 of the full-scale reading if the instrument is designed and manufactured very carefully. The lowest measurement inaccuracy value attainable is $\pm 0.002\%$.

One zerious disadvantage of this type of instrument is its lack of ruggedness. Continuous use and the inevitable shock loading that will occur from time to time both cause damage to



Figure 18.5 Beam balance (equal arm balance).

.

the knife edges, leading to deterioration in measurement accuracy and measurement resolution. A further problem affecting their use in industrial applications is that it takes a relatively long time to make each measurement. For these reasons, the beam balance is normally reserved as a calibration standard and is not used in day-to-day production environments.

Weigh beam

The weigh beam, sketched in two alternative forms in Figure 18.6, operates on similar principles to the beam balance but is much more rugged. In the first form, standard masses are added to balance the unknown mass and fine adjustment is provided by a known mass that is moved along a notched, graduated bar until the pointer is brought to the null, balance point. The alternative form has two or more graduated bars (three bars shown in Figure 18.6). Each bar



Two alternative forms of weigh beams.

carries a different standard mass, which is moved to appropriate positions on the notched bar to balance the unknown mass. Versions of these instruments are used to measure masses up to 50 tonne.

Pendulum scale

The pendulum scale is another instrument that works on the mass-balance principle. In one arrangement shown in Figure 18.7, the unknown mass is put on a platform that is attached by steel tapes to a pair of cams. Downward motion of the platform, and hence rotation of the cams, under the influence of the gravitational force on the mass, is opposed by the gravitational force acting on two pendulum-type masses attached to the cams. The amount of rotation of the cams when the equilibrium position is reached is determined by the deflection of a pointer against a scale. The shape of the cams is such that this output deflection is linearly proportional to the applied mass. Other mechanical arrangements also exist that have the same effect of producing an output deflection of a pointer moving against a scale. It is also possible to replace the pointer and scale system by a rotational displacement transducer that gives an electrical output. Various versions of the instrument can measure masses in the range between 1 kg and 500 tonne, with a typical measurement innecuracy of $\pm 0.1\%$.



Recently, the instrument has become much less common because of its inferior performance compared with instruments based on newer technology such as electronic balances. One potential source of difficulty with the instrument is oscillation of the weigh platform when mass is applied. Where necessary, in instruments measuring larger masses, dashpots are incorporated into the cam system to damp out such oscillations. A further possible problem can arise, mainly when measuring large masses, if the mass is not placed centrally on the platform. This can be avoided by designing a second platform to hold the mass, which is hung from the first platform by knife edges. This lessens the criticality of mass placement.

Electromagnetic balance

The electromagnetic balance uses the torque developed by a current-carrying coil suspended in a permanent magnetic field to balance the unknown mass against the known gravitational force produced on a standard mass, as shown in Figure 18.8. A light source and detector system is used to determine the null-balance point. The voltage output from the light detector is amplified and applied to the coil, thus creating a servosystem where deflection of the coil in equilibrium is proportional to the applied force. Its advantages over beam balances, weigh beams, and pendulum scales include its smaller size, its insensitivity to environmental changes (modifying inputs), and its electrical form of output. Despite these apparent advantages, it is no longer in common use because of the development of other instruments, particularly electronic balances.

18.2.5 Spring Balance

Spring balances provide a method of mass measurement that is both simple and inexpensive. The mass is hung on the end of a spring and deflection of the spring due to the downward gravitational force on the mass is measured against a scale. Because the characteristics of the spring are very susceptible to environmental changes, measurement accuracy is usually



relatively poor. However, if compensation is made for changes in spring characteristics, then a measurement inaccuracy less than $\pm 0.2\%$ is achievable. According to the design of the instrument, masses between 0.5 kg and 10 tonne can be measured.

18.3 Force Measurement

This section is concerned with the measurement of horizontal forces that either stretch or compress the body that they are applied to according to the direction of the force with respect to the body. If a force of magnitude, F, is applied to a body of mass, M, the body will accelerate at a rate. A, according to the equation:

$$F = MA.$$

The standard unit of force is the Newton, this being the force that will produce an acceleration of 1 meter per second squared in the direction of the force when applied to a mass of 1 kilogram. One way of measuring an unknown force is therefore to measure acceleration when it is applied to a body of known mass. An alternative technique is to measure the variation in the resonant frequency of a vibrating wire as it is tensioned by an applied force. Finally, forms of load cells that deform in the horizontal direction when horizontal forces are applied can also be used as force sensors. These techniques are discussed next.

18.3.1 Use of Accelerometers

The technique of applying a force to a known mass and measuring the acceleration produced can be carried out using any type of accelerometer. Unfortunately, the method is of very limited practical value because, in most cases, forces are not free entities but are part of a system (from which they cannot be decoupled) in which they are acting on some body that is not free to accelerate. However, the technique can be of use in measuring some transient forces and also for calibrating forces produced by thrust motors in space vehicles.

18.3.2 Vibrating Wire Sensor

This instrument, illustrated in Figure 18.9, consists of a wire that is kept vibrating at its resonant frequency by a variable-frequency oscillator. The resonant frequency of a wire under tension is given by

$$f = \frac{0.5}{L} \sqrt{\left(\frac{M}{T}\right)},$$

where M is the mass per unit length of the wire, L is the length of the wire, and T is the tension the to the applied force, F. Thus, measurement of the output frequency of the oscillator allows force applied to the wire to be calculated.





Vibrating wire sensor

18.3.3 Use of Load Cells

Special forms of electronic load cells designed to deflect in the horizontal direction are used to measure horizontal forces applied to them.

18.4 Torque Measurement

Measurement of applied torques is of fundamental importance in all rotating bodies to ensure that the design of the rotating element is adequate to prevent failure under shear stresses. Torque measurement is also a necessary part of measuring the power transmitted by rotating shafts. The four methods of measuring torque consist of (i) measuring the strain produced in a rotating body due to an applied torque, (ii) an optical method, (iii) measuring the reaction force in cradled shaft bearings, and (iv) using equipment known as the *Prony brake*. Of these, the first two should be regarded as "normal" ways of measuring torque at the present time as the latter two are no longer in common use.

18.4.1 Measurement of Induced Strain

Measuring the strain induced in a shaft due to an applied torque has been the most common method used for torque measurement in recent years. The method involves bonding four strain gauges onto a shaft as shown in Figure 18.10, where the strain gauges are arranged in a d.c. bridge circuit. The output from the bridge circuit is a function of the strain in the shaft and hence of the torque applied. It is very important that positioning of the strain



Position of torque-measuring strain gauges on a shaft.

gauges on the shaft is precise, and the difficulty in achieving this makes the instrument relatively expensive.

This inchnique is ideal for measuring the stalled torque in a shaft before rotation commences. However, a problem is encountered in the case of rotating shafts because a suitable method then has to be found for making the electrical connections to the strain gauges. One solution to this problem found in many commercial instruments is to use a system of slip rings and brushes for this, although this increases the cost of the instrument still further.

18.4.2 Optical Torque Measurement

Optical techniques for torque measurement have become available recently with the development of isser diodes and fiber-optic light transmission systems. One such system is shown in Figure 18 11. Two black-and-white striped wheels are mounted at either end of the rotating shaft and are in thighment when no torque is applied to the shaft. Light from a laser diode light source is directed by a pair of fiber-optic cables onto the wheels. The rotation of the wheels causes pulses of reflected light, which are transmitted back to a receiver by a second pair of fiber-optic cables. Under zero torque ionditions, the two pulse trains of reflected light are in phase with each other. If torque is now applied to the shaft, the reflected light is modulated. Measurement by the receiver of the phase difference letween the reflected pulse trains therefore allows the magnitude of torque in the shaft to be alculated. The cost of such instruments is relatively low, and an additional advantage in many "plications is their small physical size.

18.4.3 Reaction Forces in Shaft Bearings

System involving torque transmission through a shaft contains both a power source and a power absorber where the power is dissipated. The magnitude of the transmitted torque can be reasured by crading either the power source or the power absorber end of the shaft in bearings. If then measuring the reaction force, F, and the arm length, L, as shown in Figure 18.12.



The torque is then calculated as the simple product, FL. Pendulum scales are used very commonly for measuring the reaction force. Inherent errors in the method are bearing friction and windage torques. This technique is no longer in common use.

18.4.4 Prony Brake

The Prony brake is another torque-measuring system that is now uncommon. It is used to measure the torque in a rotating shaft and consists of a rope wound round the shaft, as illustrated in Figure 18.13. One end of the rope is attached to a spring balance and the other end carries a load in the form of a standard mass, m. If the measured force in the spring balance is F_m then the effective force, F_m exerted by the rope on the shaft is given by



 $F_e = mg - F_s$.

Figure 18.13 A Prony brake.

If the radius of the shaft is R_r , and that of the rope is R_r , then the effective radius, R_e , of the rope and drum with respect to the axis of rotation of the shaft is given by

$$R_r = R_1 + R_r.$$

The torque in the shaft, T_i can then be calculated as

$$T = F_r R_r$$

While this is a well-known method of measuring shaft torque, a lot of heat is generated because of friction between the rope and shaft, and water cooling is usually necessary

18.5 Calibration of Mass, Force, and Torque Measuring Sensors

One particular difficulty that arises in the calibration of mass, force, and torque measuring instruments is variability in the value of g (acceleration due to gravity). Apart from instruments such as the beam balance and pendulum scale, which directly compare two masses, all other instruments have an output reading that depends on the value of g.

The value of g is given by Helmert's formula:

$$g = 980.6 - 2.6\cos\phi - 0.000309h,$$

where ϕ is the latitude and h is the altitude in meters.

It can be seen from this formula that g varies with both latitude and altitude. At the equator $(\cos\phi = 0^{\circ})$, g = 978.0, whereas at the poles $(\cos\phi = 90^{\circ})$, g = 983.2. In Britain, a working value of 980.7 is normally used for g, and very little error can normally be expected when using this value. Where necessary, the exact value of g can be established by measuring the period and length of a pendulum.

Another difficulty that arises in calibrating mass, force, and torque sensors is the presence of an upward force generated by the air medium in which the instruments are tested and used. According to Archimedes' principle, when a body is immersed in a fluid (air in this case), there is an upward force proportional to the volume of fluid displaced. Even in pure mass-balance instruments, an error is introduced because of this unless both the body of unknown mass and the standard mass have the same density. This error can be quantified as

$$Error = \frac{SG_e}{SG_e} - \frac{SG_e}{SG_m},$$

where SG_{σ} is the specific gravity of air, SG_{μ} is the specific gravity of the substance being measured, and SG_{μ} is the specific gravity of the standard mass.

Fortunately, maximum error due to this upward force (which has the largest magnitude when weighing low-density liquids such as petrol) will not exceed 0.2%. Therefore, in most

of the calibration tree, where the highest levels of accuracy are demanded, either correction be made for this factor or it must be avoided by carrying out the calibration in vacuum are ditions

18.5.1 Mass Calibration

The primary requirement in mass calibration is maintenance of a set of standard masses applied to the mass sensor being calibrated. Provided that this set of standard masses is protected from damage, there is little reason for the value of the masses to change. Despite this, values of the masses must be checked at prescribed intervals, typically annually, in order to maintain the traceability of the calibration to reference standards. The instrument used to provide this calibration check on standard masses is a beam balance, a weigh beam, a pendulum scale, an electromagnetic balance, or a proof ring-based load cell.

Beam belonce

A beam balance is used for calibrating masses in the range between 10 mg and 1 kg. The measurement resolution and accuracy achieved depend on the quality and sharpness of the kmile edge that the pivot is formed from. For high measurement resolution, friction at the pivot must be as close to zero as possible, and hence a very sharp and clean knife edge pivot is demanded. The two halves of the beam on either side of the pivot are normally of equal length and are measured from the knife edge. Any bluntness, dirt, or corrosion in the pivot can cause these two lengths to become unequal, causing consequent measurement errors. Similar comments apply about the knife edges on the beam that the two pans are hung from. It is also important that ull knife edges are parallel, as otherwise displacement of the point of application of the force over the line of the knife edge can cause further measurement errors. This last form of error also occurs if the mass is not placed centrally on the pan.

Great care is therefore required in the use of such an instrument, but, provided that it is kept in pool condition, particularly with regard to keeping the knife edges sharp and clean, high measurement accuracy is achievable. Such a good condition can be confirmed by applying calibrated masses to each side of the balance. If the instrument is then balanced exactly, all is well.

Which beam

In order to use it as a calibration standard, a weigh beam has to be manufactured and maintained to a high standard. However, providing these conditions are met, it can be used as a standard for calibrating masses up to 50 tonne.

Pendulum scale

Like the weigh beam, the pendulum scale can only be used for calibration if it is manufactured to a high standard and maintained properly, with special attention to the cleanliness and lubrication of moving parts. Provided that these conditions are met, it can be used as a calibration standard for masses between 1 kg and 500 tonne.

Electromagnetic balance

Various forms of electromagnetic balance exist as alternatives to the three instruments just described for calibration duties. A particular advantage of the electromagnetic balance is its use of an optical system to magnify motion around the null point, leading to higher measurement accuracy. Consequently, this type of instrument is often preferred for calibration duties, particularly for higher measurement ranges. The actual degree of accuracy achievable depends on the magnitude of the mass being measured. In the range between 100 g and 10 kg, an inaccuracy of $\pm 0.0001\%$ is achievable. Above and below this range, inaccuracy is worse, increasing to $\pm 0.002\%$ measuring 5 tonne and $\pm 0.03\%$ measuring 10 mg.

Proof ring-based load cell

The proof ring-based load cell is used for calibration in the range between 150 kg and 2000 tonne. When used for calibration, displacement of the proof ring in the instrument is measured by either an LVDT or a micrometer. As the relationship between the applied mass/ force and the displacement is not a straight-line one, a force/deflection graph has to be used to interpret the output. The lowest measurement inaccuracy achievable is $\pm 0.1\%$.

18.5.2 Force Sensor Calibration

Force sensors are calibrated using special machines that apply a set of known force values to the sensor. The machines involved are very large and expensive. For this reason, force aensor calibration is normally devolved to either specialist calibration companies or manufacturers of the measurement devices being calibrated, who will give advice about the frequency of calibration necessary to maintain the traceability of measurements to national reference standards.

18.5.3 Calibration of Torque Measuring Systems

As for the case of force sensor calibration, special machines are required for torque measurement system calibration that can apply accurately known torque values to the system being calibrated. Such machines are very expensive. It is therefore normal to use the services of specialist calibration companies or to use similar services provided by the manufacturer of the torque measurement system. Again, the company to which the calibration task is assigned will give advice on the required frequency of calibration.

18.6 Summary

We have covered the measurement of all three quantities—mass, force, and torque—in this chapter as the three quantities are closely related. We also learned that weight was another related quantity as this describes the force exerted on a mass subject to gravity.

Mass is measured in one of three distinct ways, using load cell, using a spring balance, or using one of several instruments working on the mass-balance principle. Of these, load cells and apring balances are deflection-type instruments, whereas the mass balance is a null-type instrument. This means that a balance is somewhat tedious to use compared with other forms of mass-measuring instruments.

In respect of load cells, we looked first at the electronic load cell, as this is now the type of load cell preferred in most applications where masses between 0.1 kg and 3000 tonne in magnitude are measured. We learned that pneumatic and hydraulic load cells represent somewhat older technology that is used much less frequently nowadays. However, special types of hydraulic load cells still find a significant number of applications in measuring large masses, where the maximum capability is 50,000 tonne. We noted that variations in the local value of g (the acceleration due to gravity) have some effect on the accuracy of load cells but observed that the magnitude of this error was usually small. Before leaving the subject of load cells, we also made some mention of intelligent load cells.

Looking next at mass balance instruments, we saw that a particular advantage that they had was their immunity to variations in the value of g. We studied the various types of balance available in the form of the beam balance, weigh beam, pendulum scale, and electromagnetic balance.

We then ended the review of mass-measuring instruments by looking at the spring balance. Our conclusion about this was that, while simple and inexpensive, its measurement accuracy is multiply relatively poor.

Moving on to force measurement, we noted that transient forces could be measured by an section matter. However, static forces were measured either by a vibrating wire sensor or by a tal form of load cell.

Lumking next at torque measurement, we saw that the main two current methods for measuring torque were to measure the induced strain in a rotating shaft or measure the torque optically. Brief mention of two older techniques was made, in the form of measuring the reaction forces in the bearings supporting a rotating shaft and in using a device called the Prony brake. However, we noted that neither of these is now in common use.

We then concluded the chapter by examining the techniques used for calibrating the measuring devices covered in the chapter. We noted that calibration of mass-measuring sensors involved use of a set of standard masses. As regarding the calibration of force and torque sensors,

we saw that both of these required the use of special machines that generate a set of known force or torque values. Because such machines are very expensive, we noted that it was normal to use the services of either specialist calibration companies or the manufacturers of the measurement devices being calibrated.

18.7 Problems

- 18.1. What is the difference between mass and weight? Discuss briefly the three main methods of measuring the mass of a body.
- 18.2. Explain, using a sketch as appropriate, how each of the following forms of load cells work: (a) electronic, (b) pneumatic, (c) hydraulic, and (d) intelligent.
- 18.3. Discuss the main characteristics of the four kinds of load cells mentioned in Problem 18.2. Which form is most common, and why?
- 18.4. Discuss briefly the working characteristics of each of the following: (a) beam balance; (b) weigh beam, and (c) pendulum scale.
- 18.5. How does a spring balance work? What are its advantages and disadvantages compared with other forms of mass-measuring instruments?
- 18.6. What are the available techniques for measuring force acting in a horizontal direction?
- 18.7. Discuss briefly the four main methods used to measure torque.
- 18.8. Discuss the general principles of calibrating mass-measuring instruments.
- 18.9. Which instruments are used as a reference standard in mass calibration? What special precautions have to be taken in manufacturing and using such reference instruments?

CHAPTER 19

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19.1 Introduction

Movement is an integral part of many systems and therefore sensors to measure motion are an important tool for engineers. Motion occurs in many forms. Simple movement causes a *displacement* in the body affected by it. although this can take two alternative forms according to whether it is motion in a straight line (*translational displacement*) or angular motion about an axis (*rotational displacement*). Displacement only describes the fact that a body has moved but does not define the speed at which the motion occurs. Speed is defined by the term *velocity*. As for displacement, velocity occurs in two forms—*translational velocity* describes the speed at which a body changes position when moving in a straight line and *rotational velocity* (sometimes called *angular velocity*) describes the speed at which a body turns about the axis of rotation. Finally, it is clear that changes in velocity occur during the motion of a body. To start with, the body is at rest and the velocity is zero. At the start of motion, there is a change in velocity from zero to some nonzero value. The term *acceleration* is used to describe the rate at which the velocity changes. As for displacement and velocity, acceleration also comes in two forms—*translational acceleration* describes the rate of change of translational velocity and *rotational acceleration* (sometimes called *angular acceleration*) describes the rate of change of rotational velocity.

With motion occurring in so many different forms, a review of the various sensors used to measure these different forms of motion would not fit conveniently within a single chapter. Therefore, this chapter only reviews sensors used for measuring translational motion, with those used for measuring rotational motion being deferred to the next chapter. The following sections therefore look in turn at the measurement of translational displacement, velocity, and acceleration.

The subjects of vibration and shock are also included in final sections of this chapter. Both of these are related to translational acceleration and therefore properly belong within this chapter on translational displacement. Vibrations consist of linear harmonic motion, and measurement of the accelerations involved in this motion is important in many industrial and other environments. Shock is also related to acceleration and characterizes the motion involved when a moving body is suddenly brought to rest, often when a falling body hits the floor. This normally involves large-magnitude deceleration (negative acceleration).

19.2 Displacement

Translational displacement transducers are instruments that measure the motion of a body in a straight line between two points. Apart from their use as a primary transducer measuring the motion of a body, translational displacement transducers are also widely used as a secondary

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component in measurement systems, where some other physical quantity, such as pressure, force, acceleration, or temperature, is translated into a translational motion by the primary measurement transducer. Many different types of translational displacement transducers exist and these, along with their relative merits and characteristics, are discussed in the following sections of this chapter. Factors governing the choice of a suitable type of instrument in any particular measurement situation are considered in the final section at the end of the chapter.

19.2.1 Resistive Potentiometer

The resistive potentiometer is perhaps the best-known displacement-measuring device. It consists of a resistance element with a movable contact as shown in Figure 19.1. A voltage, V_{a} , is applied across the two ends A and B of the resistance element, and an output voltage, V_{a} , is measured between the point of contact C of the sliding element and the end of resistance element A. A linear relationship exists between the output voltage, V_{a} , and distance AC, which can be expressed by

$$\frac{V_0}{V_c} = \frac{AC}{AB}.$$
(19.1)

The body whose motion is being measured is connected to the sliding element of the potentiometer so that translational motion of the body causes a motion of equal magnitude of the slider along the resistance element and a corresponding change in the output voltage, V_{O} .

Three different types of potentiometers exist, wire wound, carbon film, and plastic film, so named according to the material used to construct the resistance element. Wire-wound potentiometers consist of a coil of resistance wire wound on a nonconducting former. As the slider moves along the potentiometer track, it makes contact with successive turns of the wire coil. This limits the resolution of the instrument to the distance from one coil to the next. Much better



Resistive potentiometer.

measurement resolution is obtained from potentiometers using either a carbon film or a conducting plastic film for the resistance element. Theoretically, the resolution of these is limited only by the grain size of the particles in the film, suggesting that measurement resolutions up to 10⁻⁴ should be attainable. In practice, resolution is limited by mechanical difficulties in constructing the spring system that maintains the slider in contact with the resistance track, although these types are still considerably better than wire-wound types.

Operational problems of potentiometers all occur at the point of contact between the sliding element and the resistance track. The most common problem is dirt under the slider, which increases the resistance and thereby gives a false output voltage reading or, in the worst case, causes a total loss of output. High-speed motion of the slider can also cause the contact to bounce, giving an intermittent output. Friction between the slider and the track can also be a problem in some measurement systems where the body whose motion is being measured is moved by only a small force of a similar magnitude to these friction forces.

VThe life expectancy of potentiometers is normally quoted as a number of reversals, that is, as the number of times the slider can be moved backward and forward along the track. The values quoted for wire-wound, carbon film, and plastic film types are, respectively, 1, 5, and 30 million. In terms of both life expectancy and measurement resolution, therefore, the carbon and plastic film types are clearly superior, although wire-wound types do have one advantage in respect of their lower temperature coefficient. This means that wire-wound types exhibit much less variation in their characteristics in the presence of varying ambient temperature conditions.

A typical inaccuracy value that is quoted for translational motion resistive potentiometers is $\pm 1\%$ of full-scale reading. Manufacturers produce potentiometers to cover a large span of measurement ranges. At the bottom end of this span, instruments with a range of ± 2 mm are available, while instruments with a range of ± 1 m are produced at the top end.

The resistance of the instrument measuring the output voltage at the potentiometer slider can affect the value of the output reading, as discussed in Chapter 3. As the slider moves along the potentiometer track, the ratio of the measured resistance to that of the measuring instrument varies, and thus the linear relationship between the measured displacement and the voltage output is distorted as well. This effect is minimized when the potentiometer resistance is small relative to that of the measuring instrument. This is achieved by (1) using a very high-impedance measuring instrument and (2) keeping the potentiometer resistance as small as possible. Unfortunately, the latter is incompatible with achieving high measurement sensitivity as this requires high potentiometer resistance. A compromise between these two factors is therefore necessary. The alternative strategy of obtaining high measurement sensitivity by keeping the potentiometer resistance low and increasing the excitation voltage is not possible in practice because of the power-rating limitation. This restricts the allowable power loss in the potentiometer to its heat dissipation capacity.

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The process of choosing the best potentiometer from a range of instruments that are evailable, taking into account power rating and measurement linearity considerations, is illustrated in the following example.

Example 19.1

The output voltage from a translational motion potentiometer of stroke length 0.1 meter is to be measured by an instrument whose resistance is 10 KΩ. The maximum measurement error, which occurs when the slider is positioned two-thirds of the way along the element (i.e., when AC = 2AB/3 in Figure 19.1), must not exceed 1% of the full-scale reading. The highest possible measurement sensitivity is also required. A family of potentiometers having a power rating of 1 watt per 0.01 meter and resistances ranging from 100 to 10 KΩ in 100-Ω steps are available. Choose the most suitable potentiometer from this range and calculate the sensitivity of measurement that it gives.

Solution

Referring to the labeling used in Figure 19.1, let the resistance of portion AC of the resistance element R_i and that of the whole length AB of the element be R_r . Also, let the resistance of the measuring instrument be R_m and the output voltage measured by it be V_m . When the voltage-measuring instrument is connected to the potentiometer, the net resistance across AC is the sum of two resistances in parallel (R_i and R_m) given by

$$R_{AE} = \frac{R_{e}R_{e}}{R_{e} + R_{e}}$$

Let the excitation voltage applied across the ends AB of the potentiometer be V and the resultant current flowing between A and B be I. Then I and V are related by

$$= \frac{V}{R_{AC} + R_{CB}} = \frac{V}{[R_{AC}/R_{t} + R_{m}] + R_{t} - R_{t}}$$

Vm can now be calculated as

$$V_{m} = IR_{AC} = \frac{VR_{i}R_{m}}{(|R_{i}R_{m}/(R_{i} - R_{m})| - R_{i} - R_{i})(R_{i} - R_{m})}$$

If we express the voltage that exists across AC in the absence of the measuring instrument as V_0 , then we can express the error due to the loading effect of the measuring instrument as error $V_0 - V_m$.

Er

From Equation (19.1), $V_{e} = (R,V)/R_{e}$. Thus,

$$\operatorname{ror} = V_{a} - V_{m}$$

$$= V\left(\frac{R_{i}}{R_{i}}\right) \left(\frac{R_{i}R_{m}}{\left(\left|R_{i}R_{m}/R_{i} + R_{m}\right| + R_{i} - R_{i}\right)\left|R_{i} + R_{m}\right|\right)} \left(\frac{R_{i}^{2}(R_{i} - R_{i})}{\left|R_{i}|R_{i}R_{i} + R_{m}R_{i} - R_{i}^{2}\right|}\right)$$

$$(10.2)$$

Substituting R, = 2R,/3 into Equation (19.2) to find the maximum error:

$$Maximum error = \frac{2R_{\star}}{2R_{\star} + 9R_{m}}$$

For a maximum error of 1%,

$$\frac{2R_s}{2R_s} = 0.01.$$

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Substituting $R_m = 10,000 \Omega$ into Equation (19.3) gives $R_c = 454 \Omega$. The nearest resistance values in the range of potentiometers available are 400 and 500 Ω . The value of 400 Ω has to be selected, as this is the only one that gives a maximum measurement error of less than 1%.

The thermal rating of the potentiometers is quoted as 1 watt/0.01 m, that is, 10 watts for a total length of 0.1 m. By Ohm's law, maximum supply voltage

 $\sqrt{power \times resistance} = \sqrt{10 \times 400} = 63.25$ Volts

Thus, the measurement sensitivity = 63.25/0.1 V/m = 632.5 V/m.

19.2.2 Linear Variable Differential Transformer (LVDT)

The linear variable differential transformer, which is commonly known by the abbreviation LVDT, consists of a transformer with a single primary winding and two secondary windings connected in the series-opposing manner shown in Figure 19.2. The object whose translational displacement is to be measured is attached physically to the central iron core of the transformer so that all motions of the body are transferred to the core.

For an excitation voltage V_i given by $V_i = V_p \sin(\omega t)$, the e.m.f.s induced in the secondary windings V_a and V_b are given by

$$V_a = K_a \sin(\omega t - \phi)$$
; $V_b = K_b \sin(\omega t - \phi)$.

Parameters K_a and K_b depend on the amount of coupling between the respective secondary and primary windings and hence on the position of the iron core. With the core in the central position, $K_a = K_b$, we have $V_a = V_b = K \sin(\omega t - \phi)$.





Figure 19.2 Linear variable differential transformer

Because of the series opposition mode of connection of secondary windings, $V_a = V_a - V_{ba}$ and hence with the core in the central position, $V_a = 0$. Suppose now that the core is displaced upward (i.e., toward winding A) by distance x. If then $K_a = K_1$ and $K_b = K_2$, we have $V_a = (K_1 - K_2)\sin(\omega t - \phi)$.

If, elternatively, the core were displaced downward from the null position (i.e., toward winding B) by distance κ , the values of K_a and K_b would then be $K_a = K_2$ and $K_b = K_1$, and we would have:

$$V_{\phi} = (K_2 - K_1) \sin(\omega t - \phi) = (K_1 - K_2) \sin(\omega t + [\pi - \phi]).$$

Thus for equal magnitude displacements +x and -x of the core away from the central (null) position, the magnitude of the output voltage, V_{m} is the same in both cases. The only information about the direction of movement of the core is contained in the phase of the output voltage, which differs between the two cases by 180°. If, therefore, measurements of core position on both sides of the null position are required, it is necessary to measure the phase as well as the magnitude of the output voltage. The relationship between the magnitude of the output voltage and the core position is approximately linear over a reasonable range of movement of the core on either side of the null position and is expressed using a constant of proportionality C as $V_{m} = Cx$.

The only moving part in an LVDT is the central iron core. As the core is only moving in the air gap between the windings, there is no friction or wear during operation. For this reason, the instrument is a very popular one for measuring linear displacements and has a quoted life expectancy of 200 years. The typical inaccuracy is $\pm 0.5\%$ of full-scale reading and measurement resolution is almost infinite. Instruments are available to measure a wide span of measurements from $\pm 100 \mu m$ to $\pm 100 mm$. The instrument can be made suitable for operation in corrosive environments by enclosing the windings within a nonmetallic barrier, which leaves

the magnetic flux paths between the core and windings undisturbed. An epoxy resin is used commonly to encapsulate the coils for this purpose. One further operational advantage of the instrument is its insensitivity to mechanical shock and vibration.

Some problems that affect the accuracy of the LVDT are the presence of harmonics in the excitation voltage and stray capacitances, both of which cause a nonzero output of low magnitude when the core is in the null position. It is also impossible in practice to produce two identical secondary windings, and the small asymmetry that invariably exists between the secondary windings adds to this nonzero null output. The magnitude of this is always less than 1% of the full-scale output and, in many measurement situations, is of little consequence. Where necessary, the magnitude of these effects can be measured by applying known displacements to the instrument. Following this, appropriate compensation can be applied to subsequent measurements.

19.2.3 Variable Capacitance Transducers

Like variable inductance, the principle of variable capacitance is used in displacementmeasuring transducers in various ways. The three most common forms of variable capacitance transducers are shown in Figure 19.3. In Figure 19.3a, capacitor plates are formed by two concentric, hollow, metal cylinders. The displacement to be measured is applied to the inner cylinder, which alters the capacitance. The second form, Figure 19.3b, consists of two flat. parallel, metal plates, one of which is fixed and one of which is movable. Displacements to be measured are applied to the movable plate, and the capacitance changes as this moves. Both of these first two forms use air as the dielectric medium between the plates. The final form, Figure 19.3c, has two flat, parallel, metal plates with a sheet of solid dielectric material between them. The displacement to be measured causes a capacitance change by moving the dielectric sheet.

Inaccuracies as low as $\pm 0.01\%$ are possible with these instruments, with measurement resolutions of 1 µm. Individual devices can be selected from manufacturers' ranges that measure displacements as small as 10^{-11} m or as large as 1 m. The fact that such instruments consist only of two simple conducting plates means that it is possible to fabricate devices that are tolerant to a wide range of environmental hazards, such as extreme temperatures, radiation, and corrosive atmospheres. As there are no contacting moving parts, there is no friction or wear in operation and the life expectancy quoted is 200 years. The major problem with variable capacitance transducers is their high impedance. This makes them very susceptible to noise and means that the length and position of connecting cables need to be chosen very carefully. In addition, very high impedance instruments need to be used to measure the value of the capacitance. Because of these difficulties, use of these devices tends to be limited to those few applications where high accuracy and measurement resolution of the instrument are required.

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Variable capacitance transducer.

19.2.4 Variable Inductance Transducers

One simple type of variable inductance transducer was shown earlier in Figure 13.4. This has a spical measurement range of 0-10 mm. An alternative form of variable inductance transducer, newn in Figure 19.4a, has a very similar size and physical appearance to the LVDT, but has a center-tapped single winding. The two halves of the winding are connected, as shown in Figure 19.4b, to form two arms of a bridge circuit that is excited with an alternating voltage. With the core in the central position, the output from the bridge is zero. Displacements of the time either side of the null position cause a net output voltage that is approximately proportional.





to the displacement for small movements of the core. Instruments in this second form are available to cover a wide span of displacement measurements. At the lower end of this span, instruments with a range of 0-2 mm are available, while at the top end, instruments with a range of 0-5 m can be obtained.

19.2.5 Strain Gauges

The principles of strain gauges were covered earlier in Chapter 13. Because of their very small range of measurement (typically 0–50 μ m), strain gauges are normally only used to measure displacements within devices such as diaphragm-based pressure sensors rather than as a primary sensor in their own right for direct displacement measurement. However, strain gauges can be used to measure larger displacements if the range of displacement measurement is extended by the scheme illustrated in Figure 19.5. In this, the displacement to be measured is applied to a wedge fixed between two beams carrying strain gauges. As the wedge is displaced downward, the beams are forced apart and strained, causing an output reading on the strain gauges. Using this method, displacements up to about 50 mm can be measured.

19.2.6 Piezoelectric Transducers

The piezoelectric transducer is effectively a force-measuring device used within many instruments designed to measure either force itself or the force-related quantities of pressure and acceleration. It is included within this discussion of linear displacement transducers because its mode of operation is to generate an e.m.f. proportional to the distance by which





Strain gauges measuring large displacements.

it is compressed. The device is manufactured from a crystal, which can be either a natural material, such as quartz, or a synthetic material, such as lithium sulfate. The crystal is muchanically stiff (i.e., a large force is required to compress it); consequently, piezoelectric transducers can only be used to measure the displacement of mechanical systems that are stiff enough themselves to be unaffected by the stiffness of the crystal. When the crystal is compressed, a charge is generated on the surface that is measured as the output voltage. Unfortunately, as is normal with any induced charge, the charge leaks away over a period of time. Consequently, the output voltage-time characteristic is as shown in Figure 19.6. Because of this characteristic, piezoelectric transducers are not suitable for measuring static or slowly varying displacements, even though the time constant of the charge-decay process can be lengthened by adding a shunt capacitor across the device.

As a displacement-measuring device, the piezoelectric transducer has a very high sensitivity, about 1000 times better than a strain gauge. Its typical inaccuracy is $\pm 1\%$ of full-scale reading and its life expectancy is three million reversals.

19.2.7 Nozzle Flapper

Denozle flapper is a displacement transducer that translates displacements into a pressure change. A secondary pressure-measuring device is therefore required within the instrument. The Deneral form of a nozzle flapper is shown schematically in Figure 19.7. Fluid at a known supply


Voltage-time characteristic of a piezoelectric transducer following step displacement.



pressure, P_m flows through a fixed restriction and then through a variable restriction formed by the gap, x, between the end of the main vessel and the flapper plate. The body whose displacement is being measured is connected physically to the flapper plate. The output measurement of the instrument is the pressure, P_m in the chamber shown in Figure 19.7, which is almost proportional to x over a limited range of movement of the flapper plate. The instrument typically has a first-order response characteristic. Air is used very commonly as the working fluid, which gives the

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instrument a time constant of about 0.1 second. The instrument has extremely high sensitivity but its range of measurement is quite small. A typical measurement range is ± 0.05 mm with a measurement resolution of ± 0.01 µm. One very common application of nozzle flappers is measuring displacements within a load cell, which are typically very small.

19.2.8 Other Methods of Measuring Small/Medium-Sized Displacements

Apart from the methods outlined earlier, several other techniques for measuring small constational displacements exist, as discussed here. Some of these involve special instruments that have a very limited sphere of application, for instance, in measuring machine tool constancements.

Linear inductosyn

A linear inductosyn is an extremely accurate instrument widely used for axis measurement and control within machine tools. Typical measurement resolution is 2.5 µm. The instrument consists of two magnetically coupled parts separated by an air gap, typically 0.125 mm wide, as shown in Figure 19.8. One part, the track, is attached to the axis along which displacements are to be



Linear inductosyn.

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measured. This would generally be the bed of a machine tool. The other part, the slider, is attached to the body that is to be measured or positioned. This would usually be a cutting tool.

The track, which may be several meters long, consists of a fine metal wire formed into the pattern of a continuous rectangular waveform and deposited onto a glass base. The typical pitch (cycle length), *s*, of the pattern is 2 mm, which extends over the full length of the track. The slider is usually about 50 mm wide and carries two separate wires formed into continuous rectangular waveforms that are displaced with respect to each other by one-quarter of the cycle pitch, that is, by 90 electrical degrees. The wire waveform on the track is excited by an applied voltage given by $V_a = V \sin(\omega t)$.

This excitation causes induced voltages in the slider windings. When the slider is positioned in the null position such that its first winding is aligned with the winding on the track, the output voltages on the two slider windings are given by $V_1 = 0$; $V_2 = V \sin(\omega t)$.

For any other position, slider winding voltages are given by $V_1 = V \sin(\omega t) \sin(2\pi x/s)$; $V_2 = V \sin(\omega t) \cos(2\pi x/s)$, where r is displacement of the slider away from the null position.

Consideration of these equations for the slider-winding outputs shows that the pattern of output voltages repeats every cycle pitch. Therefore, the instrument can only discriminate displacements of the slider within one cycle pitch of the windings. This means that the typical measurement range of an inductosyn is only 2 mm. This is of no use in normal applications, and therefore an additional displacement transducer with coarser resolution but larger measurement range has to be used as well. This coarser measurement is made commonly by translating the linear displacements by suitable gearing into rotary motion, which is then measured by a rotational displacement transducer.

One slight problem with the inductosyn is the relatively low level of electromagnetic coupling between the track and slider windings. Compensation for this is made using a high-frequency excitation voltage (5-10 kHz is common).

Translation of linear displacements into rotary motion

In some applications, it is inconvenient to measure linear displacements directly, either because there is insufficient space to mount a suitable transducer or because it is inconvenient for other reasons. A suitable solution in such cases is to translate the translational motion into rotational motion by suitable gearing. Any of the rotational displacement transducers discussed in the next chapter can then be applied.

Integration of output from velocity transducers and accelerometers

If velocity transducers or accelerometers already exist in a system, displacement measurements can be obtained by integration of the output from these instruments. However, this only gives information about the relative position with respect to some arbitrary starting point. It does not yield a measurement of the absolute position of a body in space unless all motions away from a fixed starting point are recorded.

Laser interferometer

The standard interferometer has been used for over 100 years for accurate measurement of displacements. The laser interferometer is a relatively recent development that uses a laser light source instead of the conventional light source used in a standard interferometer. The laser source extends the measurement range of the instrument by a significant amount while maintaining the same measurement resolution found in a standard interferometer. In the particular form of laser interferometer shown in Figure 19.9, a dual-frequency helium-neon (He-Ne) laser is used that gives an output pair of light waves at a nominal frequency of 5×10^{14} Hz. The two waves differ in frequency by 2×10^{6} Hz and have opposite polarization. This dual-frequency output waveform is split into a measurement beam and a reference beam by the first beam splitter.

The reference beam is sensed by the polarizer and photodetector, A, which converts both waves in the light to the same polarization. The two waves interfere constructively and destructively alternately, producing light-dark flicker at a frequency of 2×10^6 Hz. This excites a 2-MHz electrical signal in the photodetector.

The measurement beam is separated into the two component frequencies by a polarizing beam splitter. Light of the first frequency, f_1 , is reflected by a fixed reflecting cube into a photodetector and polarizer, B. Light of the second frequency, f_2 , is reflected by a movable reflecting cube and also enters B. The displacement to be measured is applied to the movable cube. With the movable cube in the null position, the light waves entering B



produce an electrical signal output at a frequency of 2 MHz, which is the same frequency as the reference signal output from A. Any displacement of the movable cube causes a Doppler shift in the frequency, f_2 , and changes the output from B. The frequency of the output signal from B varies between 0.5 and 3.5 MHz according to the speed and direction of movement of the movable cube. Outputs from A and B are amplified and subtracted. The resultant signal is fed to a counter whose output indicates the magnitude of the displacement in the movable cube and whose rate of change indicates the velocity of motion.

This technique is used in applications requiring high-accuracy measurement, such as machine tool control. Such systems can measure displacements over ranges of up to 2 m with an inaccuracy of only a few parts per million. They are therefore an attractive alternative to the inductosyn, in having both high measurement resolution and a large measurement range within one instrument.

Fotonic sensor

The fotonic sensor is one of many recently developed instruments that make use of fiber-optic techniques. It consists of a light source, a light detector, a fiber-optic light transmission system, and a plate that moves with the body whose displacement is being measured, as shown in Figure 19.10. Light from the outward fiber-optic cable travels across the air gap to the plate and some of it is reflected back into the return fiber-optic cable. The amount of light reflected back from the plate is a function of the air gap length, x, and hence of plate displacement. Measurement of the intensity of the light carried back along the return cable to the light detector allows displacement of the plate to be calculated. Common applications of fotonic sensors are measuring diaphragm displacements in pressure sensors and measuring the movement of bimetallic temperature sensors.







Noncontacting optical sensor

Figure 19.11 shows an optical technique used to measure small displacements. The motion to be measured is applied to a vane, whose displacement progressively shades one of a pair of monolithic photodiodes that are exposed to infrared radiation. A displacement measurement is obtained by comparing the output of the reference (unshaded) photodiode with that of the thaded one. The typical range of measurement is ± 0.5 mm with an inaccuracy of $\pm 0.1\%$ of full acade. Such sensors are used in some intelligent pressure-measuring instruments based on Boundon tubes or disphragms as described in Chapter 15.

19.2.9 Measurement of Large Displacements (Range Sonsors)

One final class of instruments that has not been mentioned so far comman of those designed to measure relatively large translational displacements. These are assally known as range remore and measure the motion of a body with respect to some fixed datum point. Most

range sensors use an energy source and energy detector, but measurement using a rotary potentionneter and a spring-loaded drum provides an alternative method.

Emergy source/detector-based range sensors

The fundamental components in energy source/detector-based range sensors are an energy source, an energy detector, and an electronic means of timing the time of flight of the energy between the source and the detector. The form of energy used is either ultrasonic or light, in some systems, both the energy source and the detector are fixed on the moving body and operation depends on the energy being reflected back from the fixed boundary as in Figure 19.12a, in other systems, the energy source is attached to the moving body and the energy detector is located within the fixed boundary, as shown in Figure 19.12b,

In ultranomic systems, the energy is transmitted from the source in high-frequency bursts. A frequency of at least 20 kHz is usual, and 40 kHz is common for measuring distances up to 5 m. By measuring the time of flight of the energy, the distance of the body from the fixed boundary can be calculated, using the fact that the speed of sound in air is 340 m/s. Because of difficulties in measuring the time of flight with sufficient accuracy, ultrasonic systems are not



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principle for measuring distances of loss than about 300 mm. Measurement resolution is limited by the wavelength of the ultrasonic energy and can be improved by operating at higher frequencies. At higher frequencies, however, attenuation of the magnitude of the ultrasonic wave as it passes through air becomes significant. Therefore, only low frequencies are suitable if large distances are to be measured. The typical inaccuracy of ultrasonic range finding systems is $\pm 0.5\%$ of full scale.

Optical range-finding systems generally use a laser light source. The speed of light in air is grout $3 \times 10^8 m/s$, so that light takes only a few nanoseconds to travel a meter. In consequence, such systems are only suitable for measuring very large displacements where the time of flight is long enough to be measured with reasonable accuracy.

Retary patentiometer and spring loaded drum

Another method for measuring large displacements that are beyond the measurement range of common displacement transducers is shown in Figure 19.13. This consists of a steel wise attached to the body whose displacement is being measured; the wire passes round a pulley and on to a spring-londed drum whose rotation is measured by a rotary potentiometer. A multiture potentiometer is usually required for this to give an adequate measurement production. With this measurement system, it is possible to reduce measurement uncertainty to as little as $\pm 0.01\%$ of full-scale reading.



System for measuring large displacements

19.2.10 Proximity Sensors

For the sake of completeness, it is proper to conclude this chapter on translational displacement transducers with consideration of proximity sensors. Proximity detectors provide information on the displacement of a body with respect to some boundary, but only insofar as to say whether the body is less than or greater than a certain distance away from the boundary. The output of a proximity sensor is thus binary in nature: the body is, or is not, close to the boundary.

Like range sensors, proximity detectors make use of an energy source and detector. The detector is a device whose output changes between two states when the magnitude of the incident reflected energy exceeds a certain threshold level. A common form of proximity sensor uses an infrared light-eraiting diode (LED) source and a phototransistor. Light triggers the transistor into a conducting state when the LED is within a certain distance from a reflective boundary and the reflected light exceeds a threshold level. This system is physically small, accupying a volume of only a few cubic centimeters. If even this small volume is obtainive, then fiber-optic cables can be used to transmit light from a remetely mounted LED and phototransistor. The threshold displacement detected by optical proximity sensors can be varied between 0 and 2 m.

Another form of proximity sensor uses the principle of varying inductance. Such devices are particularly suitable for operation in aggressive environmental conditions and can be made vibration and shock resistant by vacuum encapsulation techniques. The sensor contains a high-frequency oscillator whose output is demodulated and fed via a trigger circuit to an amplifier output stage. The oscillator output radiates through the surface of the sensor and, when the sensor surface becomes close to an electrically or magnetically conductive boundary, the output voltage is reduced because of interference with the flux paths. At a certain point, the output voltage is reduced sufficiently for the trigger circuit to change state and reduce the amplifier output to zero. Inductive sensors can be adjusted to change state at displacements in the range of 1 to 20 mm.

A third form of proximity rennor uses the capacitive principle. These can operate in similar conditions to inductive types. The threshold level of displacement detected can be varied between 5 and 40 mm.

Fiber-optic proximity sensors also exist where the amount of reflected light varies with the proximity of the fiber ends to a boundary, as shown earlier in Figure 13.2c.

19.2.11 Choosing Translational Measurement Transducers

Choice between the various translational motion transducers available for any particular application depends manualy on the magnitude of the displacement to be measured, although the operating environment is also relevant.

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The requirement to measure displacements of less than 2 mm usually occurs as part of an intervation that is measuring some other physical quantity, such as pressure, and several types of devices have evolved to fulfill this task. The LVDT, strain gauges, fotonic sensor, variable capacitance transducers, and noncontacting optical transducer all find application is measuring disphragm or Bourdon tube displacements within pressure transducers. Load cell displacements are also very small, which are commonly measured by nozzle flapper devices.

For measurements within the range of 2 mm to 2 m, the number of suitable instruments grows. Both the relatively inexpensive potentiometer and the LVDT, which is somewhat more expensive, are commonly used for such measurements. Variable inductance and variable especiance transducers are also used in some applications. Additionally, strain gauges measuring the strain in two beams forced apart by a wedge (see Section 19.2.5) can measure displacements up to 50 mm. If very high measurement resolution is required, either the linear inductory or the laser interferometer is used.

Finally, range sensors are normally used if the displacement to be measured exceeds 2 meters.

As well as choosing tensors according to the magnitude of displacement to be measured, the measurement environment is also sometimes relevant. If the environmental operating conditions are severe (e.g., hot, radioactive or corrosive atmospheres), devices that can be protected easily from these conditions must be chosen, such as the LVDT, variable inductance, and variable capacitance instruments.

19.2.12 Calibration of Translational Displacement Moasurement Transducers

Most translational displacement transducers measuring displacements up to 50 mm can be enlibrated at the workplace level using standard micrometers to measure a set of displacements and comparing the reading from the displacement transducer being calibrated when it is reading the same set of displacements. Such micrometers can provide a reference standard with an intecuracy of $\pm 0.003\%$ of full-scale reading. If better accuracy is required, micrometer-based calibrators are available from several manufacturers that reduce the measurement inaccuracy down to $\pm 0.001\%$ of full-scale reading.

For nearons that measure displacements exceeding 50 mm (including those classified as range nearons), the usual calibration tool is a baser interferometer. This can provide measurement increments to $\pm 0.0002\%$ of full-scale reading. According to which laser interferometer model is chosen, a measurement range up to 50 meters is possible. Obviously, laser interferometers in expensive devices, which are also physically very large for a model measuring up to 50 meters, and therefore calibration services using these are usually devolved to specialist calibration campanies or instrument nameforum.

19.3 Velocity

Translational velocity cannot be measured directly and therefore must be calculated indirectly by other means as set out here.

19.3.1 Differentietten of Displacement Measurements

Differentiation of position measurements obtained from any of the translational displacement transducers described in Section 19.2 can be used to produce a translational velocity mgnal. Unfortunately, the process of differentiation always amplifies noise in a measurement system. Therefore, if this method has to be used, a low-noise instrument such as a d.c.-excited carbon film potentiometer or later interferometer should be chosen. In the case of potentiometers, i.c. excitation must be avoided because of the problem that harmonics in the power supply would cause.

19.3.2 Integration of Output of an Accelerameter

Where an accelerometer is already included within a system, integration of its output can be performed to yield a velocity signal. The process of integration atteauates rather than amplifies measurement noise, and this is therefore an acceptable technique in terms of measurement accuracy.

19.3.3 Conversion to Rotational Velocity

Conversion from translational to rotational velocity is the final measurement technique open to the system designer and is the one used most commonly. This conversion enables any of the rotational velocity-measuring instruments described in Chapter 20 to be applied.

19.3.4 Calibration of Valacity Measurement Systems

Because translational velocity is never measured directly, the calibration procedure used depends on the system used for velocity measurement. If a velocity measurement is being calculated from a displacement or acceleration measurement, the traceability of system calibration requires that the associated displacement or acceleration transducer used is calibrated corractly. The only other measurement technique is conversion of the translational velocity into rotational velocity, in which case the system calibration depends on the calibration of the rotational velocity transducer used.

19.4 Acceleration

The only class of device available for meaning acceleration is the accelerometer. These are prolable in a wide variety of types and ranges designed to meet particular measurement requirements. They have a frequency response between zero and a high value, and have a form of output that can be integrated readily to give displacement and velocity measurements. The frequency response of accelerometers can be improved by altering the level of damping in the instrument. Such adjustment must be done carefully, however, because frequency response improvements are only achieved at the expense of degrading the measurement sensitivity. In addition to their use for general-purpose motion measurement, accelerometers are widely used to measure mechanical shocks and vibrations.

Most forms of accelerometer consist of a mass suspended by a spring and damper inside a housing, as shown in Figure 19.14. The accelerometer is fastened rigidly to the body undergoing acceleration. Any acceleration of the body causes a force. F_m on the mass, M, given by $F_n = M\bar{x}$.

This force is opposed by the restraining effect, F_{μ} of a spring with spring constant K, and the not gesult is that mass is displaced by a distance, x, from its starting position such that $F_{\mu} = Kx$.

In stendy state, when the mass inside is accelerating at the same rate as the case of the accelerometer, $F_{a} = F_{a}$ and so

$$Kx = M\ddot{x} \quad \text{er} \quad \ddot{x} = (Kx)/M. \tag{19.4}$$

This is the equation of motion of a second-order system, and, in the absence of damping, the output of the accelerometer would consist of nondecaying oscillations. A damper is therefore included within the instrument, which produces a damping force, F_{ch} proportional to the



Structure of an accelerometer.

velocity of the mass, M_s given by $F_d = Bz$. This modifies the previous equation of motion [Equation (19.4)] to the following:

 $Kx + Bx = M\bar{x} \tag{19.5}$

One important characteristic of accelerometers is their sensitivity to accelerations at right angles to the sensing axis (the direction along which the instrument is designed to measure acceleration). This is defined as *cross-senalsivity* and is specified in terms of the output, expressed as a percentage of full-scale output, when an acceleration of some specified magnitude (e.g., 30g) is applied at 90° to the sensing axis.

The acceleration reading is obtained from the instrument by measurement of the displacement of the mass within the accelerometer. Many different displacement-measuring techniques are used in the various types of accelerometers available commercially. Different types of accelerometers also vary in terms of the type of spring element and form of damping used.

Reminive potention sters are one such displacement-measuring instrument used in accelerometers. These are used mainly for measuring slowly varying accelerations and low-frequency vibrations in the range of 0-50g. The measurement resolution obtainable is about 1 in 400 and typical values of cross-sensitivity are $\pm 1\%$. Inaccuracy is about $\pm 1\%$ and life expectancy is quoted at two million reversals. A typical size and weight are 125 cm³ and 500 gram.

Strain gauges and piezorenistive sensors are also used in accelerometers for measuring accelerations up to 200g. These serve as the spring element as well as measuring mass displacement, thus simplifying the instrument's construction. Their typical characteristics are a resolution of 1 in 1000, inaccuracy of $\pm 1\%$, and cross-sonsitivity of 2%. They have a major advantage over potentiometer-based accelerometers in terms of their much smaller size and weight (3 cm³ and 25 gram).

Another displacement transducer found in accelerometers is the LVDT. This device can measure accelerations up to 700g with a typical inaccuracy of \pm 1% of full scale. They are of a similar physical size to potentiometer-based instruments but are lighter in weight (100 gram).

Accelerometers based on variable-inductance displacement-measuring devices have exstensely good characteristics and are suitable for measuring accelerations up to 40g. Typical specifications of such instruments are inaccuracy $\pm 0.25\%$ of full scale, resolution 1 in 10,000, and crossnensitivity of 0.5%. Their physical size and weight are similar to potentiometer-based devices lastruments with an output in the form of a varying capacitance also have similar characteristics.

The other common displacement transducer used in accelerometers is the piezoslectric type. The major advantage of using piezoslectric crystals is that they also act as the spring and damper within the instrument. In consequence, the device is quite small (15 cm⁻¹) and low mass (50 gram), but because of the nature of a piezoslectric crystal operation, such lastruments

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are not mitable for measuring constant or dowly time-varying accelerations. As the electrical impedance of a piezoelectric crystal is itself high, the output voltage must be measured with a very high-impedance instrument to avoid loading effects. Many recent piezoelectric crystal-based accelerometers incorporate a high impedance charge amplifier within the body of the instrument. This simplifies the signal conditioning requirements external to the accelerometer but can lead to problems in certain operational environments became these internal electronics are exposed to the same environmental hazards as the rest of the pocelerometer. Typical measurement resolution of this class of accelerometer is 0.1% of full scale with an inaccuracy of $\pm 1\%$. Individual instruments are available to cover a wide parge of measurements from 0.03g full scale up to 1000g full scale. Intelligent accelerometers are also now available that give even better performance through inclusion of processing power to compensate for environmentally induced errors.

Recently, very small microsensors have become available for measuring acceleration. These consist of a small mass subject to acceleration mounted on a thin silicon membrane. Displacements are measured either by piezoresistors deposited on the membrane or by eaching a variable capacitor plate into the membrane.

Two forms of fiber-optic-based accelerometers also exist. One form measures the effect on light transmission intensity caused by a mass subject to acceleration resting on a multimode fiber. The other form measures the change in phase of light transmitted through a monsmode fiber that has a mass subject to acceleration resting on it.

19.4.1 Selection of Accelerometers

In choosing between the different types of accelerometers for a particular application, the mass of the instrument is particularly important. This should be very much less than that of the body whose motion is being measured in order to avoid loading effects that affect the accuracy of the readings obtained. In this respect, instruments based on strain gauges are best.

19.4.2 Colibration of Accelerometers

The primary method of calibrating accelerometers is to mount them on a table rotating about a vertical axis such that the sensing axis of the accelerometer is pointing toward the axis of solution of the table. Acceleration, a_i is then given by

$$a=r(2\pi v)^2,$$

where r is the radius of rotation measured from the center of the rotating table to the center of the needer or the needer or needer mass and r is the velocity of rotation of the table (in revolutions per second).

This obviously requires that the rotational speed of the table is measured accurately by a calibrated sensor. Provided that this condition is met, various reference acceleration values can be generated by changing the rotational speed of the table.

19.5 Vibration

19.5.1 Nature of Vibration

Vibrations are encountered very commonly in the operation of stachinery and industrial plants, and therefore measurement of the accelerations associated with such vibrations is extremely important is industrial environments. The peak accelerations involved in such vibrations can be 100g or greater in magnitude, while both the frequency of oscillation and the magnitude of displacements from the equilibrium position in vibrations have a tendency to vary randomly. Vibrations someally consist of linear harmonic motion that can be expressed mathematically as

$$X = X_{o} \sin(\cos t), \tag{19.6}$$

where X is the displacement from the equilibrium position at any general point in time, X_o is the peak displacement from the equilibrium position, and ∞ is the angular frequency of the oscillations. By differentiating Equation (19.6) with respect to time, an expression for the velocity v of the vibrating body at any general point in time is obtained as

$$\mathbf{v} = -i\mathbf{n}\mathbf{X}_{\sigma}\cos(\omega t). \tag{19.7}$$

Differentiating Equation (19.7) again with respect to time, we obtain an expression for the acceleration, α , of the body at any general point in time as

$$\alpha = -\omega^2 X_e \sin(\omega t). \tag{19.8}$$

Inspection of Equation (19.8) shows that peak acceleration is given by

$$\mathbf{x}_{\text{exert}} = \mathbf{c} \mathbf{r}^2 \mathbf{X}_{\text{e}}.\tag{19.9}$$

This square law relationship between peak acceleration and oscillation frequency is the season why high values of acceleration occur during relatively low-frequency oscillations. For example, an oscillation at 10 Hz produces peak accelerations of 2g.

Example 19.2

A pipe carrying a fluid vibrates at a frequency of 50 Hz with displacements of 8 mm from the equilibrium position. Calculate the peak acceleration.

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Solution

From Equation (19.9), $z_{\text{max}} = \omega^2 \chi_s = (2\pi 50)^2 \times (0.008) = 789.6 \text{m/s}^2$.

Using the fact that standard acceleration due to gravity, g, is $9.81m/s^2$, this answer can be expressed alternatively as $x_{max} = 789.6/9.81 = 80.5g$.

19.5.2 Vibration Measurement

It is apparent that the intensity of vibration can be measured in terms of displacement, velocity, or acceleration. Acceleration is clearly the best parameter to measure at high frequencies. However, because displacements are large at low frequencies according to Equation (19.9), it would seem that measuring either displacement or velocity would be best at low frequencies. The amplitude of vibrations can be measured by various forms of Gaplacement transducers. Fiber-optic-based devices are particularly attractive and can give measurement resolution as high as 1 μ m. Unfortunately, there are considerable practical difficulties in mounting and calibrating displacement and velocity transducers and therefore they are rarely used. Because of this, vibration is usually measured by accelerometers at all frequencies. The most common type of transducer used is the piezoaccelerometers, which has typical inaccuracy levels of $\pm 2\%$.

The frequency response of accelerometers is particularly important in vibration measurement in vibration to the inherently high-frequency characteristics of the measurement situation. The handwidth of both potentiometer-based accelerometers and accelerometers using variable inflatance-type displacement transducers only goes up to 25 Hz. Accelerometers that include either the LVDT or strain gauges can measure frequencies up to 150 Hz, and the latest infimments using plezoresistive strain gauges have bandwidths up to 2 kHz. Finally, inclusion plezoelectric crystal displacement transducers yields an instrument with a bandwidth that can be as high as 7 kHz.

When measuring vibration, consideration must be given to the fact that attaching an accelerometer to the vibrating body will significantly affect the vibration characteristics if the body has a small mass. The effect of such "loading" of the measured system can be quantified by the following equation:

$$a_1 = a_b \left(\frac{m_b}{m_b + m_a} \right),$$

where a_1 is the acceleration of the body with accelerometer attached, a_0 is the acceleration of the body without the accelerometer, m_0 is the mass of the accelerometer, and a_0 is the mass of the body. Such considerations emphasize the advantage of piezoaccelerometers for measuring vibration, as these have a lower mass than other forms of accelerometers and so contribute least to this system-loading effect.



Vibration measurement system

As well as an accelerometer, a vibration measurement system requires other elements to translate the accelerometer output into a recorded signal, as shown in Figure 19.15. The three other necessary elements are a signal conditioning element, a signal analyzer, and a signal recorder. The signal-conditioning element amplifies the relatively weak output signal from the accelerometer and also transforms the high output impedance of the accelerometer to a lower impedance value. The signal analyzer then converts the signal into the form required for output. The output parameter may be displacement, velocity, or acceleration, and this may be expressed as peak value, r.m.s. value, or average absolute value. The final element of the measurement system is the signal recorder. All elements of the measurement system, especially the signal recorder, must be chosen very carefully to avoid distortion of the vibration waveform. The bandwidth should be such that it is at least a factor of 10 better than the bandwidth of the vibration frequency components at both ends. Thus its lowest frequency limit should be less than or equal to 0.1 times the fundamental frequency of vibration and its upper frequency limit should be greater than or equal to 10 times the highest significant vibration frequency component.

If the frequency of vibration has to be known, the stroboscope is a satisfile instrument to measure this. If the stroboscope is made to direct light pulses at the body at the same frequency as the vibration, the body will apparently stop vibrating.

19.5.3 Collibration of Vibration Seasors

Calibration of the accelerometer used within a vibration measurement system is normally carried out by mounting the accelerometer in a back-to-back configuration with a referencecalibrated accelerometer on an electromechanically excited vibrating table.

19.6 Shock

Shock describes a type of motion where a moving body is brought suddenly to rest, often because of a collision. This is very common in industrial situations, and usually involves a body being dropped and histing the floor. Shocks characteristically involve large-magnitude discelerations (e.g., 500g) that last for a very short time (e.g., 5 ms). An instrument having a very high frequency response is required for shock measurement, and, for this reason, piezoelectric crystal-based accelerometers are commonly used. Again, other elements for analyzing and recording the signal are required as shown in Figure 19.16 and described in the last section. A storage oscilloscope is a suitable instrument for recording the output signal, as this allows fince duration as well as acceleration levels in the shock to be measured. Alternatively, if a permanent record is required, the screen of a standard oscilloscope can be photographed.

Example 19.3

A body is dropped from a height of 10 m and suffers a shock when it hits the ground. If the duration of the shock is 5 ms, calculate the magnitude of the shock in terms of g.



Shock measurement

Solution

The equation of motion for a body falling under gravity gives the following expression tor terminal velocity, v:

$$v = \sqrt{2gx}$$

where x is the height through which the body falls. Having calculated v, the average deceleration during the collision can be calculated as $\alpha = v/t$, where t is the time duration of the shock. Substituting the appropriate numerical values into these expressions:

 $v = \sqrt{(2 \times 9.81 \times 10)} = 14.0 m/s$; x = 14.0/0.005 = 2801 m/s = 286g

19.6.1 Calibration of Shock Sonsors

Calibration of the accelerometer used within a shock sensor is carried out frequently using a pneumatic shock exciter. This device consists of a piston within a circular tube. High-pressure are is applied to one face of the piston, but it does not move initially because it is held at the end of the tube by a mechanical latching mechanism. When the latch is released, the piston accelerates at a high rate until it is brought to rest by a padded anvil at the other end of the tube. The accelerometer being calibrated and a calibrated reference accelerometer are both mounted on the anvil. By varying the characteristics of the padding, the deceleration level and hence magnitude of the shock produced on the apvil can be varied.

19.7 Summary

This chapter has been concerned with the measurement of translational (in a straight line) motion. This can take the form of displacement, velocity (rate of change of displacement), or neceleration (rate of change of velocity. We have looked at sensors for measuring each of them and, in the case of acceleration, we have also studied vibration and shock measurement. as hold of these involve acceleration measurement.

Our study of displacement nensors started with the resistive potentionneter, where we learned that potentiometers come in three different forms: wire wound, carbon film, and plastic film. We then moved on to look at the linear variable differential transformer, variable capacitance and variable inductance sensors. We noted that storing gauges were used to measure very small displacements (typically up to 50 µm in megnitude). We also noted that force-measuring piezoelectric sensors could also be regarded an displacement sensors, as their mode of operation is to generate an e.m.f. that is proportional to the distance by which it is compressed by the apforce. We also discussed the nozzle flapper, which measures displacements by converting into a pressure change. We then moved on to mammarize some other techniques for measure

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and medium-sized displacements, including translating linear motion into notational integrating the output from velocity and acceleration sensors, and using specialist such as the linear inductoryn, laser interferometer, fotonic sensor, and noncontacting trical sensor. Moving the discussion on to the measurement of relatively large displacements, noted that this could be achieved by several devices commonly called range sensors. We also included nome mention of proximity sensors, as these belong property within the classification displacement sensors, although they are a special case in that their binary form of output ity indicates whether the sensor is, or is not, within some threshold distance of a boundary. The law is boundary, before leaving the subject of displacement measurement, we looked at the techniques and the classification.

Constitution of translational velocity measurement introduced us to the fact that this cannot be measured directly. We then went on to look at the only three ways to measure it, there being direction of position measurements, integration of the output of an accelerometer, and interestion from translational to rotational velocity. Finally, we considered how measurements immed via each of the techniques could be calibrated.

in the case of acceleration measurement, we observed that this could only be measured by name form of acceleration measurement, we observed that this could only be measured by anne form of accelerations. We noted that attributes such as frequency response and croasmultivity were important as well as measurement accuracy in accelerameters. We discovered that almost all accelerations work on the principle that a mass inside them displaces when multivity on acceleration. Acceleraters differ mainly in the technique used to measure this must displacement, and we looked in turn at devices that use the resistive potentiometer, strain page, plezorestative nersor, LVDT, variable inductance sensor, and variable capacitance restore, mapectively. We then looked at the one exception to the rule that accelerometers contain a moving mass. This is the piezoelectric accelerometer. Finally, we looked at the primary multion of calibrating accelerometers using a rotating table.

We then concluded the chapter by looking at vibration and shock measurement. Both of these available accelerations, and therefore both need as accelerometer to quantify their magnitude. Insting with vibration, we noted that this was a common phenomenon, especially in industrial mattimes. We learned that vibration consists of a littear harmonic in which the peak acceleration on exceed 100g and where the oscillation frequency and peak amplitude can vary randomly. In Baled that the amplitude of vibration could be calculated from a measurement of the peak acceleration, and we went on to look at the writability of various forms of accelerometers for the measurement.

Finally, we considered shock measurement. This revealed that very large magnitude decelerations worked in the phenomenon of shock, which typically occurs when a falling body hits the a collision occurs between two solid objects. A high-frequency response is particularly the shock measurement, and the most estable device to measure this is a piezoelectric standard acceleration.

19.8 Problems

- 19.1. Discuss the mode of operation and characteristics of a linear motion potentionneter.
- 19.2. What is an LVDT? How does it work?
- 19.3. Explain how the following two instruments work and discuss their main operating characteristics and uses: (a) variable capacitance transducer and (b) variable inductance transducer.
- 19.4. Sketch a linear inductosyn. How does it work? What are its main characteristics?
- 19.5. What is a later interferometer and what are its principal characteristics? Explain how is works with the aid of a sketch.
- 19.6. What are range sensors? Describe two main types of range sensors.
- 19.7. Discuss the main types of proximity sensors available, mentioning particularly their suitability for operation in harsh savironments.

19.8. What are the main considerations in choosing a translational motion transducer for a particular application? Give examples of some types of translational motion transducers and the applications that they are suitable for.

- 19.9. Discuss the usual calibration procedures for translational motion transducers.
- 19.10. What are the main ways of measuring translational velocities? How are such measurements calibrated?
- 19.11. What are the principles of operation of a lucar motion accelerometer? What features would you expect to see in a high-quality accelerometer?
- 19.12. What types of displacement sensors are used within accelerometers? What are the relative merits of these alternative displacement sensors?
- 19.13. Write down a mathematical equation that describes the phenomenon of vibration. Explain briefly the three main ways of measuring vibration.
- 19.14. When an accelerometer is attached to a vibrating body, it has a loading effect that alters the characteristics of the vibration. Write down a mathematical equation that describes this loading effect. How can this loading effect be minimized?

CHAPTER 20

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20.1 Introduction

The different forms of motion have already been explained in the introduction to the last chapter. In that introduction, it was explained that motion occurred in two forms. These translational motion, which describes the movement of a body along a single axis, and rotational motion, which describes the motion of a body about a single axis. Because the number of sensors involved in motion measurement is quite large, the review of them is divised into two chapters. The last chapter described translational motions notational motion can now this chapter describes rotational motion sensors. Again, as for translational motion, notational motion can occur in the form of displacement, velocity, or acceleration, which are considered separately in the following sections.

20.2 Rotational Displacement

Rotational displacement transducers measure the angular motion of a body about some rotation axis. They are important not only for measuring the rotation of bodies such as shafts, but also as a part of systems that measure translational displacement by converting the translational motion to a rotary form. The various devices available for measuring rotational displacements are presented here, and arguments for choosing a particular form in any given measurement atuation are considered at the end of the chapter.

20.2.1 Circular and Halical Potentiomators

The circular potentiometer is the least expensive device available for measuring rotational displacements. It works on almost exactly the same principles as the translational motion potentiometer except that the track is bent round into a circular shape. The measurement rate of individual devices varies from 0-10° to 0-360° depending on whether the track forms a full circle or only part of a circle. Where a greater measurement range than 0-360° is required, a *helical potentiometer* is uned. The helical potentiometer accommodates multiple turns of the track by forming the track into a helix shape, and some devices are able to measure up to 60 full revolutions. Unfortunately, the greater mechanical complexity of a helical potentiometer makes the device significantly more expensive than a circular potentiometer. The two forms of devices are shown in Figure 20.1,

Both kinds of devices give a linear relationship between the measured quantity and the output reading because the output voltage measured at the sliding contact is proportional to the angular displacement of the slider from its starting position. However, as with linear interpretations potentional potentionsters can give performance problems if dirt on the track causes loss of contact. They also have a limited life because of wear between sliding surfaces. The typical inaccuracy of this class of devices varies from $\pm 1\%$ of full scale for circular potentionneters down to $\pm 0.002\%$ of full scale for the between sliding potentionneters.



Rotary motion potentiometers: (a) circular and (b) helical.

20 2.2 Retational Differential Transformer

This is a special form of differential transformer that measures rotational rather than translational nation. The method of construction and connection of the windings is exactly the same as for the baser variable differential transformer, except that a specially shaped care is used that varies the matual inductance between the windings as it rotates, as shown in Figure 20.2. Like its linear around its the instrument suffers no wear in operation and therefore has a very long life with dmont no maintenance requirements. It can also be modified for operation in barsh environments by and soing the windings inside a protective enclosure. However, apart from the difficulty of eventing nome asymmetry between the secondary windings, great care has to be taken in these maturents to machine the core to exactly the right shape. In consequence, the inaccuracy cannot be mediced below $\pm 1\%$, and even this level of accuracy is only obtained for limited excursions of the care $\pm 40^\circ$ away from the null position. For angular displacements of $\pm 60^\circ$, the typical



Rotary differential transformer

inncoursely rises to $\pm 3\%$, and the instrument is unsuitable for measuring displacements greater than this.

20.2.3 Incremental Shaft Encoders

Incremental shaft encoders are one of a class of encoder devices that give an output in digital form. They measure the instantaneous angular position of a shaft relative to some arbitrary datum point, but are anable to give any indication about the absolute position of a shaft. The principle of operation is to generate pulses as the shaft whose displacement is being measured rotates. These pulses are counted and total angular rotation is inferred from the pulse count. The pulses are generated either by optical or by magnetic means and are detected by suitable nensors. Of the two, the optical system is considerably less exponence and therefore much more common. Such instruments are very convenient for computer control applications, as the meanumment is already in the required digital form and therefore the analogue-to-digital signal convenient process required for an analogue sensor is avoided.

An example of an optical incremental shaft encoder is shown in Figure 20.3. It can be seen that the instrument consists of a pair of discs, one of which is fixed and one of which rotates with the body whose angular displacement is being meansed. Each disc is banically opaque but has a pattern of windows cut into it. The fixed disc has only one window and the light source is aligned with this so that the light shines through all the time. The second disc has two tracks of windows cut into it that are spaced equidistantly around the disc, as





Window arrangement in incremental shaft encoder.

shown in Figure 20.4. Two light detectors are positioned beyond the second disc so that one is aligned with each track of windows. As the second disc rotates, light alternately enters and does not enter the detectors, as windows and then opaque regions of the disc pass in front of them. These pulses of light are fed to a counter, with the final count after motion has ceased corresponding to the angular position of the moving body relative to the intring position. The primary information about the magnitude of rotation is obtained by the detector aligned with the outer track of windows. However, the pulse count obtained from this gives no information about the direction of rotation. The necessary direction information is provided by the second, inner track of windows, which have an angular displacement with respect to the outer set of windows therefore lag or lead the primary set of pulses according to the direction of rotation.

The unskimum measurement resolution obtainable is limited by the number of windows that can be machined onto a dinc. The maximum number of windows per track for a 150-mminteger dinc in 5000, which gives a basic angular measurement resolution of 1 in 5000. By using more sophisticated circuits that increment the count on both the rising and the falling migns of the pulses through the outer track of windows, it is possible to double the resolution to a limit mean of 1 in 10,000. At the expense of even greater complexity in the counting circuit, it is

also possible to include pulses from the inner track of windows in the count, so giving a maximum measurement resolution of 1 in 20,000.

Optical incremental diaft encoders are a popular instrument for measuring relative angular displacements and are very reliable. Problems of noise in the system giving false counts can nonsetimes cause difficulties, although this can usually be eliminated by squaring the output from the light detectors. Such instruments are found in many applications where rotational motion has to be measured. Incremental shaft encoders are also used commonly material encoder where a translational displacement has been transformed to a rotational one by suitable gearing. One example of this practice is in measuring the translational motions in numerically controlled drilling machines. Typical gearing used for this would give one revolution per millimeter of translational displacement. By using an incremental shaft encoder with 1000 windows per track in such an arrangement, a measurement resolution of 1 pm is obtained.

20.2.4 Coded Disc Shaft Encoders

Unlike the incremental shaft encoder that gives a digital output in the form of pulses that have to be counted, the digital shaft encoder has an output in the form of a binary number of neveral digits that provides an absolute measurement of shaft position. Digital encoders provide high accuracy and reliability. They are particularly useful for computer control applications, but have a significantly higher cout than incremental encoders. Three different forms exist, using optical, electrical, and magnetic energy systems, respectively.

Optical digital shaft encoder

The optical digital shaft encoder is the least expensive form of encoder available and is the one used most commonly. It is found in a variety of applications; one where it is particularly popular is in measuring the position of rotational joints in robot manipulators. The instrument is similar in physical appearance to the incremental shaft encoder. It has a pair of diacs (one movable and one fixed) with a light source on one side and light detectors on the other side, as shown in Figure 20.5. The fixed diac has a single window, and the principal way in which the device differs from the incremental shaft encoder is in the design of the windows on the movable diac, as shown in Figure 20.6. There are cut in four or more tracks instead of two and are arranged in acctors as well as tracks. An energy detector is aligned with each track, and these give an output of "1" when energy is detected and an output of "0" otherwise. The measurement resolution obtainable depends on the mumber of tracks used. For a four-track version, the resolution is 1 in 16, with progressively higher measurement resolution being attained as the number of tracks is increased. These binary outputs from the detectors are combined together to give a binary number of several digits. The number of digits corresponds to the member of tracks on the director is contained to the example shown in Figure 20.6, is four. The pattern of windows in each sector is cut

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Window arrangement for coded disc shaft encoder.

Each that as that particular soctor passes across the window in the fixed disc, the four energy detector outputs combine to give a unique binary sumber. In the binary-coded example shown in Figure 20.6, the binary member output increments by one as each sector in the rotating disc. Plates in ture across the window in the fixed disc. Thus the output from sector 1 is 0001, from textor 2 is 0010, from sector 3 is 0011, etc.

While this arrangement is perfectly adequate in theory, serious problems can arise in practice due to the manufacturing difficulty involved in machining the windows of the movable diac such that the edges of the windows in each track are aligned exactly with each other. Any misalignment means that, as the disc turns across the boundary between one sector and the next, the outputs from each track will switch at alightly different instants of time, and therefore the binary number output will be incorrect over small angular ranges corresponding to the sector boundaries. The worst error can occur at the boundary between sectors 7 and 8, where the output is switching from 0111 to 1000. If the energy sensor corresponding to the first digit tiches before the others, then the output will be 1111 for a vary small angular range of movement, indicating that sector 15 is aligned with the fixed disc rather than sector 7 or 8. This represents an error of 100% in the indicated angular position.

In practice, there are two ways that are used to overcome this difficulty. Both of these solutions involve an alteration to the manner in which windows are machined on the movable disc, as shown in Figure 20.7. The first method adds an extra outer track on the disc, known as an *antiambiguity track*, which consists of small windows that span a small angular range on either side of each sector boundary of the main track system. When energy sensors associated with this extra track sense energy, this is used to signify that the disc is aligned on a sector boundary and the output is unreliable. The second method is somewhat simpler and less expensive because it avoids the expense of machining the extra antiambiguity track. It does this by using a special code, known as the *Gray code*, to cut the tracks in each sector on the movable disk. The Gray code is a special binary representation where only one binary digit changes in moving from one decimal number representation to the next, that is, from one sector to the next in the digital shaft encoder. The code is illustrated in Table 20.1.



Pigure 28.7 Modified window errangements for a rotating disc.

Bannal Number	Hanny Code	Gray Cade
0	0000	0990
1	0001	0001
2	0010	0011
3	0011	0910
4	0100	0110
5	0104	0111
6	0110	0101
7	0113	0100
E	1000	1180
	1004	1101
10	1010	1111
11	1011	1110
12	1108	1910
13	1100	1011
14	1110	1001
15	1118	1000

Table 20.1 The Gray Code

It is possible to manufacture optical digital shaft encoders with up to 21 tracks, which gives a measurement resolution of 1 part in 10⁶ (about 1 second of arc). Unfortunately, a high cost is involved in the special photolithography techniques used to cut the windows in order to achieve such a measurement resolution, and very high-quality mounts and bearings are needed. Hence, such devices are very expensive.

Contexturg (electrical) digital shaft encoder

The contacting digital shaft encoder consists of only one disc, which rotates with the body whose displacement is being measured. The disc has conducting and nonconducting tegments instead of the transparent and opaque areas found on the movable disc of the optical form of instrument, but these are arranged in an identical pattern of sectors and tracks. The disc is charged to a low potential by an electrical brush in contact with one side of the disc, and a set of brushes on the other side of the disc measures the potential in each track. The output of each detector brush is interpreted as a binary value of "1" or "0" necording to whether the track in that particular segment is conducting or not and hence whether a voltage is sensed or not. As for the case of the optical form of instrument, these outputs are combined together to give a multibit binary number. Contacting digital shaft incoders have a similar cost to the equivalent optical instruments and have operational informations in sovere environmental conditions of high temperature or mechanical shock. They suffer from the meant problem of output ambiguity at the sector boundaries but his problem is overcome by the using are indicated instruments.

A serious problem is the application of contacting digital shaft encoders arises from their use of brushes. These introduce friction into the measurement system, and the combination of dirt and brush wear causes contact problems. Consequently, problems of intermittent output can occur, and such instruments generally have limited reliability and a high maintenance cost. Measurement resolution is also limited because of the lower limit on the minimum physical size of the contact brushes. The maximum number of tracks possible is 10, which limits the resolution to 1 part in 1000. Thus, contacting digital shaft encoders are normally only used where the environmental conditions are too severe for optical instruments.

Magnetic digital shaft encoder

Magnetic digital shaft encoders consist of a single rotatable disc, as in the contacting form of encoder discussed in the previous section. The pattern of sectors and tracks consists of magnetically conducting and nonconducting segments, and the sensors aligned with each track consist of small toroidal magnets. Each of these sensors has a coil wound on it that has a high or low voltage induced in it according to the magnetic field close to in. This field is dependent on the magnetic conductivity of that segment of the disc closest to the toroid.

These instruments have no moving parts in contact and therefore have a nimilar reliability to optical devices. Their major advantage over optical equivalents is an ability to operate in very harsh environmental conditions. Unfortunately, the process of manufacturing and accurately aligning the toroidal magnet sensors required makes such instruments very expensive. Their use is therefore limited to a few applications where both high measurement resolution and also operation in harsh environments are required.

20.2.5 The Resolver

The resolver, also known as a synchro-resolver, is an electromechanical device that gives an analogue output by transformer action. Physically, resolvers resemble a small a.c. motor and have a diameter ranging from 10 to 100 mm. They are frictionless and reliable in operation because they have no contacting moving surfaces; consequently, they have a long life. The best devices give measurement resolutions of 0.1%.

Resolvers have two stator windings, which are mounted at right angles to one another, and a rotor, which can have either one or two windings. As the angular position of the rotor changes, the output voltage changes. The simpler configuration of a resolver with only one winding in a rotor is illustrated in Figure 20.8. This exists in two separate forms that are distinguished according to whether the output voltage changes in amplitude or changes in phase as the rotor rotates relative to the stator winding.



Schematic representation of resolver windings.

Kaying amplitude output randver

The stator of this type of resolver is excited with a single-phase simuoidal voltage of frequency a, where the amplitudes in the two windings are given by

$$V_1 = V \sin(\beta) \quad ; \quad V_2 = V \cos(\beta),$$

where $V = V_1 \sin(\omega t)$.

The effect of this is to give a field at an angle of $(\beta + \pi/2)$ relative to stator winding 1.

Suppose that the angle of the rotor winding relative to that of the stator winding is given by 0. Then the magnetic coupling between the windings is a maximum for $\theta = (\beta + \pi/2)$ and a minimum for $(\theta = \beta)$. The rotor output voltage is of fixed frequency and varying amplitude given by

$$V_{\alpha} = KV_{A} \cos(\beta - \theta) \sin(\omega t).$$

This metationship between shaft angle position and output voltage is nonlinear, but approximate linearity is obtained for small angular motions where $||| - ||| < 15^{\circ}$.

Intelligent variables of this type of resolver are available that use a microprocessor to process time and cosine outputs. This can improve the measurement resolution to 2 minutes of arc.

Varying phase output reacher

This is a less common form of resolver that is only used in a few applications. The stator windings are excited with a two-phase sinusoidal voltage of frequency s, and the instantaneous voltage amplitudes in the two windings are given by

$$V_1 = V_1 \sin(\omega t)$$
; $V_2 = V_1 \sin(\omega t + \pi/2) = V_1 \cos(\omega t)$.

The net output voltage in the rotor winding is the sum of the voltages induced due to each stator winding. This is given by

$$V_{\theta} = KV_{\theta} \sin(\omega t) \cos(\theta) + KV_{\theta} \cos(\omega t) \cos(\pi/2 - \theta)$$

= $KV_{\theta} [\sin(\omega t) \cos(\theta) + \cos(\omega t) \sin(\theta)]$
= $KV_{\theta} \sin(\omega t + \theta)$

This represents a linear relationship between shaft angle and the phase shift of the rotor output relative to the stator excitation voltage. The accuracy of shaft rotation measurement depends on the accuracy with which the phase shift can be measured. This can be improved by increasing the excitation frequency, ω , and it is possible to reduce inaccuracy down to $\pm 0.1\%$. However, increasing the excitation frequency also increases magnetizing losses. Consequently, a compromise excitation frequency of about 400 Hz is used.

20.2.6 The Synchro

Like the resolver, the synchro is a motor-like, electromechanical device with an analogue output. Apart from having three stator windings instead of two, the instrument is similar in appearance and operation to the resolver and has the same range of physical dimensions. The rotor usually has a dambbell shape and, like the resolver, can have either one or two windings.

Synchros have been in use for many years for the measurement of angular positions, especially in military applications, and achieve similar levels of accuracy and measurement resolution to digital encoders. One common application is axis measurement in machine tools, where the translational motion of the tool is translated into a rotational displacement by mitable gearing. Synchros are tolerant to high temperatures, high humidity, shock, and vibration and are therefore suitable for operation in such harsh environmental conditions. Some maintenance problems are associated with the slip ring and brush system used to supply power to the rotor. However, the only major source of error in the instrument is asymmetry in the windings, and a reduction of measurement inaccuracy down to $\pm 0.5\%$ is samily achievable.

Figure 20.9 shows the sampler form of a synchro with a single rotor winding. If an a.c. excitation voltage is applied to the rotor via slip rings and brushes, this sets up a certain pattern



Schematic representation of synchro windings.

of fluxes and induced voltages in the stator windings by transformer action. For a rotor excitation voltage, V_{m} given by

$$V_{r} = V \min(\alpha t)$$

the voltages induced in the three stator windings are

 $V_1 = V \sin(\omega t) \sin(\beta) \quad ; \quad V_2 = V \sin(\omega t) \sin(\beta + 2\pi/3) \quad ;$ $V_3 = V \sin(\omega t) \sin(\beta - 2\pi/3)$

where β is the angle between the rotor and stator windings.

If the notor is tarmed at constant velocity through one full revolution, the voltage waveform induced in each stator winding is as shown in Figure 20.10. This has the form of a carsermodulated waveform, in which the carrier frequency corresponds to the excitation frequency, m. It follows that if the rotor is stopped at any particular angle, β' , the peak-to-peak amplitude of the stator voltage is a function of β' . If therefore the stator winding voltage is measured, peak-angly as its root-mean-squared (r.m.s.) value, this indicates the magnitude of the rotor rotation have from the null position. The direction of rotation is determined by the phase difference between the stator voltages, which is indicated by their relative instantaneous magnitudes.



Although a single synchro is able to measure an angular displacement by itself, it is much more common to find a pair of them used for this purpose. When used in pairs, one member of the pair is known as the synchro transmitter and the other as the synchro transformer, and the two sets of stator windings are connected together, as shown in Figure 20.11. Each synchro is of the form shown in Figure 20.9, but the rotor of the transformer is fixed for displacement-measuring applications. A sinusoidal excitation voltage is applied to the rotor of the transmitter, setting up a pattern of fluxes and induced voltages in the transmitter stator windings. These voltages are transmitted to the transformer stator windings, where a similar flax pattern is established. This is turn causes a sinusoidal voltage to be induced in the fixed transformer rotor winding. For an excitation voltage, $V \sin(\omega t)$, applied to the transmitter rotor, the voltage measured in the transformer rotor is given by

$$V_{\theta} = V \sin(\omega t) \sin(\theta)$$

where θ is the relative angle between the two rotor windings.

Apart from their use as a displacement transducer, such synchro pairs are commonly used to transmit angular displacement information over some distance, for instance, to transmit gyro compass measurements in an sircraft to remote meters. They are also used for load positioning allowing a load connected to the transformer rotor shaft to be controlled remotely by turning the



transmitter rotor. For these applications, the transformer rotor is free to rotate, and it is also tamped to prevent oscillatory motions. In the simplest arrangement, a common sinusoidal excitation voltage is applied to both rotors. If the transmitter rotor is turned, this causes an induction of the magnetic flux patterns and results in a torque on the transformer rotor that rends to bring it into line with the transmitter rotor. This torque is typically small for small displacements, so this technique is only useful if the load torque on the transformer shaft is very small. In other circumstances, it is necessary to incorporate the synchro pair within a survemechanism, where the output voltage induced in the transformer rotor winding is surplified and applied to a servomotor that drives the transformer rotor shaft until it is aligned with the transmitter shaft.

20.2.7 The Induction Potentiometer

The induction potentiometer belongs to the same class of instruments as resolvers and synchros. It only has one rotor winding and one stator winding, but otherwise it is of similar size and appearance to other devices in this class of electromechanical, angular position measuring instruments. A single-phase sinusoidal excitation is applied to the rotor winding, which causes an output voltage in the stator winding through the mutual inductance linking the two windings. The imagnitude of this induced stator voltage varies with rotation of the rotor. The variation of the output with rotation is naturally sinusoidal if the coils are wound such that their field is concentrated at one point, and only small excursions can be made away from the null position if the output relationship is to remain approximately linear. However, if the rotor and stator windings are distributed around the circumference in a special way, an approximately linear minimum plationship for angular displacements of up to $\pm 90^\circ$ can be obtained.

20.2.8 The Rotery Inductoryn

This instrument is similar in operation to the linear inductosyn, except that it measures rotary implacements and has tracks that are arranged radially on two circular discs, as shown in Figure 20.12. Typical diameters of the instrument vary between 75 and 300 mm. The larger versions give a measurement resolution of up to 0.05 second of arc. However, like its linear indications, the rotary inductosyn has a very small measurement range. Therefore, a lower resolution, rotary displacement transducer with a larger measurement range must be used in conjunction with it.

20.2.9 Gyracapes

Opencopes measure both absolute angular displacement and absolute angular velocity. Until excently, the mechanical, spinning-wheel gyroscope had a dominant position in the Marketplace. However, this position is now being challenged by optical gyroscopes.




Rotary inductoryn

Mechanical gyroscopes

Mechanical gyroscopes consist essentially of a large, motor-driven wheel whose angular momentum is such that the axis of rotation tends to remain fixed in space, thus acting as a reference point. The gyro frame is attached so the body whose motion is to be measured. The output is measured in terms of the angle between the frame and the axis of the spinning wheel. Two different forms of mechanical gyroscopes are used for measuring angular displacement—the free gyro and the me-integrating gyro. A third type of mechanical gyroscope, the rate gyro, measures angular velocity and is described in Section 20.3,

The free gyroscope is illustrated in Figure 20.13. This measures the absolute angular rotation about two perpendicular axes of the body to which its frame is attached. Two alternative methods of driving the wheel are used in different versions of the instrument. One of these is to enclose the wheel in stator-like coils that are excited with a sinusoidal voltage. A voltage is applied to the wheel via slip rings at both ends of the spindle carrying the wheel. The wheel behaves as a rotor, and motion is produced by motor action. The other, less common, method is to fix vanes on the wheel, which is then driven by directing a jet of air onto the vanes.

The free gyroscope can measure angular displacements of up to 10° with a high accuracy. For greater angular displacements, interaction between the measurements on the two perpendicular axes starts to cause a serious loss of accuracy. The physical size of the coils in the motor-actiondriven system also limits the measurement range to 10°. For these seasons, this type of gyroscope is only suitable for measuring rotational displacements of up to 10°. A further operational problem of free gyroscopes is the presence of angular drift (precession) due to bearing friction torque. This has a typical magnitude of 0.5° per manute and means that the instrument can only be used over short time intervals of say 5 minutes. This time duration can be extended if the angular momentum of the spinning wheel is increased.





A major application of the free gyroscope is in inertial navigation systems. Only two free gyros mounted along orthogonal axes are needed to monitor motions in three dimensions because each instrument measures displacement about two axes. The limited angular range of measurement is not usually a problem in such applications, as control action prevents the error in the direction of motion about any axis ever exceeding one or two degrees. However, precession is a much greater problem, and, for this reason, the rate-integrating gyro is used much more commonly.

The nute-integrating gyroscope, or integrating gyro as it is commonly known, is illustrated in Figure 20.14. It measures angular displacements about a single axis only, and therefore three instruments are required in a typical inertial navigation system. The major advastage



Figure 20.14 Rate-integrating gyroscope

of the instrument over the free gyro is the almost total absence of precession, with typical specifications quoting drifts of only 0.01°/hour. The instrument has a first-order type of response given by

$$\frac{\partial_s}{\partial_t}(D) = \frac{K}{\tau D + 1},$$
(20.1)

where $K = H/\beta$, $\tau = M/\beta$, θ_i is the input angle, θ_o is the output angle, D is the D operator. H is the angular momentum, M is the moment of inertia of the system about the measurement axis, and β is the damping coefficient.

Inspection of Equation (20.1) shows that to obtain a high value of measurement sensitivity. K. a high value of H and a low value of β are required. A large H is normally obtained by driving the wheel with a hysteresis-type motor revolving at high speeds of up to 24,000 rpm. However, damping coefficient β can only be reduced so far because a small value of β results in a large value for the system time constant, τ , and an unacceptably low speed of system response. Therefore, the value of β has to be chosen as a compromise between these constraints.

In addition to their use as a fixed reference in inertial guidance systems, integrating gyros are also used commonly within aircraft autopilot systems and in military applications such as ambilizing weapon systems in tanks.

Optical proscopes

Optical gyroscopes are a relatively recent development and come in two forms-ring laser avroscope and fiber-optic gyroscope.

The ring laser gyroscope consists of a glass ceramic chamber containing a helium-neon gamixture in which two laser beams are generated by a single anode/twin cathode system, as shown in Figure 20.15. Three mirrors, supported by the ceramic block and mounted in a triangular arrangement, direct the pair of laser beams around the cavity in opposite directions. Any rotation of the ring affects the coherence of the two beams, raising the frequency of one and lowering the frequency of the other. The clock wise and anticlock wise beams are directed into a photodetector that measures the beat frequency according to the frequency difference, which is proportional to the angle of rotation. The advantages of the ring laser gyroscope over traditional, mechanical gyroscopes are considerable. The measurement accuracy obtained is mbatantially better than that afforded by mechanical gyros in a similar price range. The device is also considerably smaller physically, which is of considerable benefit in many applications.

The fiber-optic gyroscope measures angular velocity and is described in Section 20.3,



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20.2.10 Choics between Retetional Displacement Transducers

Choice between the various rotational displacement transducers that might be used in any particular measurement situation depends first of all on whether absolute measurement of angular position is required or whether the measurement of rotation relative to some arbitrary starting point is acceptable. Other factors affecting the choice between instruments are the required measurement range, resolution of the transducer, and measurement accuracy afforded.

Where only measurement of relative angular position is required, the incremental encoder is a very suitable instrument. The best commercial instruments of this type can measure rotations to a resolution of 1 part in 20,000 of a full revolution, and the measurement range is an infinite number of revolutions. Instruments with such a high measurement resolution are very expensive, but much less expensive versions are available according to what lower level of measurement resolution is acceptable.

All the other instruments presented in this chapter provide an absolute measurement of angular position. The required measurement range is a dominant factor in the choice between these. If this exceeds one full revolution, then the only instrument available is the helical potentiometer. Such devices can measure rotations of up to 60 full turns, but are expensive because the procedure involved in manufacturing a helical resistance element to a reasonable standard of accuracy is difficult.

For measurements of less than one full revolution, the range of available instruments widens. The least expensive one available is the circular potentiomster, but much better measurement accuracy and resolution are obtained from coded-disc encoders. The least expensive of these is the optical form, but certain operating environments necessitate the use of the alternative contacting (electrical) and magnetic versions. All types of coded disc encoders are very reliable and are particularly attractive in computer control schemes, as the output is in digital form. A varying phase output resolver is yet another instrument that can measure angular displacements up to one full revolution in magnitude. Unfortunately, this instrument is expensive because of the complicated electronics incorporated to measure the phase variation and convert it to a varying amplitude output signal, and hence it is no longer in common use.

An even greater range of instruments becomes available as the required measurement range is reduced further. These include the synchro $(\pm 90^\circ)$, the varying amplitude output resolver $(\pm 90^\circ)$, the induction potentiometer $(\pm 90^\circ)$, and the differential transformer $(\pm 40^\circ)$. All these instruments have a high reliability and a long service life.

Finally, two further instruments are available for satisfying special measurement requirements—the rotary inductosyn and the gyroscope. The rotary inductosyn is used in applications where very high measurement resolution is required, although the measurement range afforded is extremely small and a conner resolution instrument must be used in parallel with it to extend the measurement range. Gyroscopes, in both mechanical and optical forms, are used to measure small angular displacements up to $\pm 10^{\circ}$ in magnitude in inertial mavigation systems and similar applications.

20.2.11 Calibration of Rotational Displacement Transducers

The coded disc shaft encoder is normally used for the calibration of rotary potentionisters and differential transformers. A typical model provides a reference standard with a measurement uncertainty of $\pm 0.1\%$ of the full-scale reading. If greater accuracy is required, for example, in calibrating encoders of lesser accuracy, encoders with measurement uncertainty dows to $\pm 0.0001\%$ of the full-scale reading can be obtained and used as a reference standard, although these have a very high associated cost.

20.3 Rotational Velocity

The main application of rotational velocity transducers is in speed control systems. They also provide the usual means of measuring translational velocities, which are transformed into rotational motions for measurement purposes by suitable gearing. Many different instruments and techniques are available for measuring rotational velocity as presented here.

20.3.1 Digital Tachemeters

Digital tachometers or, to give them their proper title, digital tachometric generators are usually noncontact instruments that sense the passage of equally spaced marks on the surface of a rotating disk or shaft. Measurement resolution is governed by the number of marks around the chroamference. Various types of sensors are used, such as optical, inductive, and magnetic ones. As each mark is aensed, a pulse is generated and input to an electronic pulse counter. Usually, velocity is calculated in terms of the pulse count in unit time, which of course only yields information about the mean velocity. If the velocity is changing, instantaneous velocity can be calculated at each instant of time that an output pulse occurs, using the scheme shown in Figure 20.16. In this circuit, each pulse from the transducer initiates the transfer of a train of clock pulses from a 1-MHz clock into a counter. Control logic resets the counter and updates the digital output value after receipt of each transducer pulse. The measurement resolution of this system is highest when the speed of rotation is low.

Optical monoing

Digital tachometers with optical sensors are often known as optical tachometers. Optical pulses can be generated by one of the two alternative photoelectric techniques illustrated in Figure 20.17. In the scheme shown in Figure 20.17s, pulses are produced as windows in a



slotted disc pass in sequence between a light source and a detector. The alternative scheme, shown in Figure 20.17b, has both a light source and a detector mounted on the same side of a reflective disc that has black sectors painted onto it at regular angular intervals. Light sources are normally either lasers or light-emitting diodes, with photodiodes and phototransistors being used as detectors. Optical tachometers yield better accuracy than other forms of digital tachometers. However, they are less reliable than other forms because dust and dirt can block light paths.

Inductive sensing

Variable reluctance velocity transducers, also known as induction tachometers, are a form of digital tachometer that use inductive sensing. They are widely used in the automotive industry within antiakid devices, antilock braking systems, and traction control. One relatively simple and inexpensive form of this type of device was described earlier in Section 13.4 (Figure 13.2). A more sophisticated version, shown in Figure 20.18, has a rotating disc constructed from a bonded fiber material into which soft iron poles are inserted at regular intervals around its periphery. The sensor consists of a permanent magnet with a shaped pole piece, which carries a wound coil. The distance between the pickup and the outer perimeter of the disc is typically 0.5 mm. As the disc rotates, the soft iron inserts on the disc move in turn past the pickup unit. As each iron insert moves toward the pole piece, the reluctance of the magnetic circuit increases and hence the flux in the pole piece also increases. Similarly, the flux in the pole piece decreases as each iron insert moves away from the sensor. The changing magnetic flux inside the pickup coil causes a voltage to be induced in the coil whose magnitude is proportional to the rate of change of flux. This voltage is positive while the flux is increasing and negative while it is



Figure 20.18 Variable reluctance transducer

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decreasing. Thus, the output is a sequence of positive and negative pulses whose frequency is proportional to the rotational velocity of the disc. The maximum angular velocity that the instrument can measure is limited to about 10,000 r.p.m. because of the finite width of the induced pulses. As the velocity increases, the distance between pulses is reduced; at a certain velocity, the pulses start to overlap. At this point, the pulse counter ceases to be able to distinguish separate pulses. The optical tachometer has significant advantages in this respect, as the pulse width is much sarrower, allowing measurement of higher velocities.

A simpler and less expensive form of variable reluctance transducer also exists that uses a ferromagnetic gear wheel in place of a fiber disc. The motion of the tip of each gear tooth toward and away from the pickup unit causes a similar variation in the flux pattern to that produced by iron inserts in the fiber disc. However, pulses produced by these means are less sharp and, consequently, the maximum angular velocity measurable is lower.

Magnetic (Hall-offect) sensing

The rotating element in Hall-effect or magnetostrictive tachometers has a very simple design in the form of a toothed metal gear wheel. The sensor is a solid-state, Hall-effect device that is placed between the gear wheel and a permanent magnet. When an intertooth gap on the gear wheel is adjacent to the sensor, the full magnetic field from the magnet passes through it Later, as a tooth approaches the sensor, the tooth diverts some of the magnetic field, and so the field through the sensor is reduced. This causes the sensor to produce an output voltage proportional to the rotational speed of the gear wheel.

20.3.2 Strobescopic Methods

The stroboscopic technique of rotational velocity measurement operates on a similar physical principle to digital tachometers except that the pulses involved consist of flashes of light generated electronically and whose frequency is adjustable so that it can be matched with the frequency of occurrence of some feature on the rotating body being measured. This feature can either be some naturally occurring one, such as gear teeth or spokes of a wheel, or be an artificially created pattern of black and white stripes. In either case, the rotating body appears stationary when frequencies of the light pulses and body features are in synchronism. Flashing rates available in commercial stroboscopes vary from 110 up to 150,000 per minute according to the range of velocity measurement required, and typical measurement lanceuracy is $\pm 1\%$ of the reading. The instrument is usually in the form of a hand-held device that is pointed toward the rotating body.

It must be noted that measurement of the flashing rate at which the rotating body appears stationary does not automatically indicate the rotational velocity, because synchronism also occurs when the flashing rate is some integral submultiple of the rotational speed. The practical reprocedure followed is therefore to adjust the flashing rate until synchronism is obtained at the largest flashing rate possible, R_1 . The flashing rate is then decreased carefully until synchronism is again achieved at the next lower flashing rate, R_2 . The rotational velocity is then given by

$$V=\frac{R_1R_2}{R_1-R_2}$$

20.3.3 Analogue Tachometers

Analogue tachometers are less accurate than digital tachometers but are nevertheless still used accessfully in many applications. Various forms exist.

The *d.c.* tachometer has an output approximately proportional to its speed of rotation. Its basic structure is identical to that found in a standard d.c. generator used for producing power and is shown in Figure 20, 19. Both permanent magnet types and separately excited field types are used. However, certain aspects of the design are optimized to improve its accuracy as a nord-measuring instrument. One significant design modification is to reduce the weight of the rotor by constructing the windings on a hollow fiberglass shell. The effect of this is to minimize any loading effect of the instrument on the system being measured. The d.c. output voltage from the instrument is of a relatively high magnitude, giving a high measurement munitivity that is typically 5 volts per 1000 r.p.m. The direction of rotation is determined by the polarity of the output voltage. A common range of measurement is 0-6000 r.p.m. Maximum mailmearity is usually about $\pm 1\%$ of the full-scale reading. One problem with these devices that can cause difficulties under some circumstances is the presence of an a.c. ripple in the output signal. The magnitude of this can be up to 2% of the output d.c. level.



Figure 20.19 A d.c. tachometer





The *a.c.* tachometer has an output approximately proportional to rotational speed like the d.c. tachogenerator. Its mechanical structure takes the form of a two-phase induction motor, with two stator windings and (usually) a drag-cup rotor, as shown in Figure 20.20. One of the stator windings is excited with an a.c. voltage, and the measurement signal is taken from the output voltage induced in the second winding. The magnitude of this output voltage is zero when the rotor is stationary, and otherwise is proportional to the angular volocity of the rotor. The direction of rotation is determined by the phase of the output voltage, which switches by 180° as the direction reverses. Therefore, both the phase and the magnitude of the output voltage have to be measured. A typical range of measurement is 0-4000 s.p.m., with an inaccuracy of $\pm 0.05\%$ of full-scale roading. Less expensive versions with a squirrel cage rotor also exist, but measurement inaccuracy in these is typically $\pm 0.25\%$.

The drag-cup tachometer, also known as an eddy-current tachometer, has a central spindle carrying a permanent magnet that rotates inside a nonmagnetic drag cup consisting of a cylindrical sleeve of electrically conductive material, as shown in Figure 20.21. As the spindle and magnet rotate, voltage is induced that causes circulating eddy currents in the cup. These currents interact with the magnetic field from the permanent magnet and produce a torque. In response, the drag cup turns until the induced torque is balanced by the torque due to the restraining springs connected to the cup. When equilibrium is reached, angular displacement of the cup is proportional to the rotational velocity of the central spindle. The instrument has a typical measurement inaccuracy of $\pm 0.5\%$ and is used commonly in the speedometers of motor vehicles and also as a speed indicator for aero-engines. It is capable of measuring velocities up to 15,000 r.p.m.

Analogue output forms of the variable relactance velocity transducer (see Section 20.3.1) also exist in which output voltage pulses are converted into an analogue, varying-amplitude. d.c. voltage by means of a frequency-to-voltage convertes circuit. However, the measurement accuracy is inferior to digital output forms.



20.3.4 The Rate Gyroscope

The rate gyro, illustrated in Figure 20.22, has an almost identical construction to the rateintegrating gyro (Figure 20.14) and differs only by including a spring system that acts as an additional restraint on the rotational motion of the frame. The instrument measures the absolute ingular velocity of a body and is widely used for generating stabilizing signals within vehicle invigation systems. The typical measurement resolution given by the instrument is 0.01%, and rotation rates up to 50% is can be measured. The angular velocity, α , of the body is related to the angular deflection of the gyroscope, θ , by the equation:

$$\frac{\theta}{\alpha}(D) = \frac{H}{MD^2 + \beta D + K},$$
(20.2)

where *H* is the angular momentum of the spinning wheel, *M* is the moment of inertia of the system, β is the viscous damping coefficient, *K* is the spring constant, and *D* is the D operator.

This relationship [Equation (20.2)] is a second-order differential equation, and we must consequently expect the device to have a response typical of second-order instruments, an discussed in Chapter 2. Therefore, the instrument must be designed carefully so that the output 556 Chapter 20



Figure 20.22 Rate gyroscope

response is neither oscillatory nor too slow in reaching a final reading. To assist in the design process, it is useful to re-express Equation (20.2) in the following form:

$$\frac{1}{\alpha}(D) = \frac{1}{D^2/\omega^2 + 2\xi D/\omega + 1},$$
and $\zeta = \frac{1}{2}$
(20.3)

where K' = H/K, $\omega = \sqrt{K/M}$, and $\zeta = \frac{1}{2\sqrt{KM}}$

The static sensitivity of the instrument, K', is made as large as possible by using a high-speed motor to spin the wheel and so make H high. Reducing the spring constant K further improves the sensitivity, but this cannot be reduced too far as it makes the resonant frequency to of the

instrument too small. The value of β is usually chosen such that the damping ratio ξ is as close to 0.7 as possible.

20.3.5 Fiber-Optic Gyroscope

This is a relatively new instrument that makes use of fiber-optic technology. Incident light from a source is separated by a beam splitter into a pair of beams, a and b, as shown in Figure 20.23. These travel in opposite directions around an fiber-optic coil (which may be several hundred meters long) and emerge from the coil as beams marked a' and b'. The beams a' and b' are directed by the beam splitter into an interferometer. Any motion of the coil causes a phase shift between a' and b', which is detected by the interferometer.

20.3.6 Differentiation of Angular Displacement Measurements

Angular velocity measurements can be obtained by differentiating the output signal from angular displacement transducers. Unfortunately, the process of differentiation amplifies any noise in the measurement signal, and therefore this technique has been used only rarely in the past. However, the technique has become more feasible with the advent of intelligent instruments. For example, using an intelligent instrument to differentiate and process the output from a resolver can produce a velocity measurement with a maximum inaccuracy of $\pm 1\%$.



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20.3.7 Integration of Output from an Accelerometer

In measurement systems that already contain an angular acceleration transducer, it is possible to obtain a velocity measurement by integrating the acceleration measurement signal. This produces a signal of acceptable quality, as the process of integration attenuates any measurement noise. However, the method is of limited value in many measurement situations because the measurement obtained is the average velocity over a period of time rather than a profile of the instantaneous velocities as motion takes place along a particular path.

20.3.8 Choice between Rotestional Velocity Transducers

Choice between different rotational velocity transducers is influenced strongly by whether an analogue or digital form of output is required. Digital output instruments are now widely used and a choice has to be made among the variable reluctance transducer, devices using electronic light pulse-counting methods, and the stroboscope. The first two of these are used to measure angular speeds up to about 10,000 r.p.m. and the last one can measure speeds up to 25,000 r.p.m.

Probably the most common form of analogue output device used is the d.c. tachometer. This is a relatively simple device that measures speeds up to about 5000 r.p.m. with a maximum inaccuracy of $\pm 1\%$. Where better accuracy is required within a similar range of speed measurement, a.c. tachometers are used. The squirrel cage rotor type has an inaccuracy of only $\pm 0.25\%$, and drag-cup rotor types can have inaccuracies as low as $\pm 0.05\%$.

The drag-cup tachometer also has an analogue output, but has a typical inaccuracy of $\pm 5\%$. However, it is inexpensive and therefore suitable for use in vehicle speedometers where an inaccuracy of $\pm 5\%$ is normally acceptable.

20.3.9 Calibration of Rotational Velocity Transducers

The main device used as a calibration standard for rotational velocity transducers is a stroboscope. Provided the flash frequency of the reference stroboscope is calibrated properly, it is possible to provide velocity measurements where the inaccuracy is less than $\pm 0.1\%$.

20.4 Rotational Acceleration

Rotational accelerometers work on very similar principles to translational motion accelerometers. They consist of a rotatable mass mounted inside a housing attached to the accelerating, rotating body. Rotation of the mass is opposed by a torsional spring and damping. Any acceleration of the housing causes a torque, $J\bar{\theta}$, on the mass. This torque is opposed by a backward torque due to the torsional spring and in equilibrium:

$$J\theta = K\theta$$
 and hence: $\theta = k\theta/J$.

A damper is usually included in the system to avoid undying oscillations in the instrument. This adds an additional backward torque, $B\theta$, to the system and the equation of motion becomes

$$J\theta = B\theta + K\theta.$$

Different manufacturers produce accelerometers that measure the angular displacement of the mass within the accelerometer in different ways. However, it should be noted that the number of manufacturers producing rotational accelerometers is substantially less than the number manufacturing translational motion accelerometers because the requirement to measure rotational acceleration occurs much less frequently than requirements to measure translational acceleration.

20.4.1 Calibration of Rotational Accelerometers

This is normally carried out by comparison with a reference standard rotational accelerometer. The task is usually delegated to specialist calibration companies or accelerometer manufacturers, because of the relatively small number of applications for rotational accelerometers and the corresponding shortage of personnel having the necessary calibration skills.

20.5 Summary

Having discussed sensors for measuring translational motion in the previous chapter, this chapter has been concerned with the measurement of the three aspects—displacement, velocity, and acceleration—of rotational motion. Starting with sensors for measuring rotation displacement, we first discussed circular and helical potentiometers. Next we considered the merits of the rotational differential transformer, incremental shaft encoder, coded disc shaft encoder, resolver, synchro, induction potentiometer, rotary inductosyn, and both free and rate-integrating gyroscopes.

Moving on to the measurement of rotational velocity, we first explored the various forms of digital tachometers available. Discussion then moved on to stroboscopic methods, followed by a review of analogue tachometers, which we noted were less accurate than digital tachometers but still in fairly widespread use. Next, we covered the two forms of gyroscopes that measure rotational velocity—rate gyro and fiber-optic gyro. Finally, we found that a velocity measurement could be obtained by differentiating an angular displacement measurement or by integrating an acceleration measurement. However, we noted that while the latter is acceptable because the process of integration attenuates any measurement noise, the differentiation technique is not

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used unless done within an intelligent instrument that can deal with the noise amplification that is inherent when measurements are obtained via differentiation.

Our final subject in the chapter was the measurement of rotational acceleration. We noted that rotational accelerometers worked on very similar principles to their translational motion counterparts, while observing that the requirement of measure rotational acceleration did not commonly arise.

20.6 Problems

- 20.1. Using simple sketches to support your explanation, explain the mode of operation and characteristics of the following devices: circular potentiometer, helical potentiometer, and rotary differential transformer.
- 20.2. Sketch an incremental shaft encoder. Explain what it measures and how it works. What special design features can be implemented to increase the measurement resolution of a disc of a given diameter?
- 20.3. What is a coded disc shaft encoder? How does its output differ from that of an incremental shaft encoder? What are the main types of coded disc shaft encoders?
- 20.4. Discuss the mode of operation of an optical coded disc shaft encoder, illustrating your discussion by means of a sketch.
- 20.5. What is the main consequence of any misalignment of the windows in an optical coded diac shaft encoder? Describe two ways in which the problem caused by window misalignment can be overcome.
- 20.6. Explain what a resolver is in the context of rotational position measurement. Discuss the two alternative forms of resolvers that exist.
- 20.7. How does a synchro work? Illustrate your explanation with a simple sketch.
- 20.8. What is a gyroscope? Discuss the characteristics and mode of operation of three kinds of gyroscopes that can measure angular position.
- 20.9. Explain the mode of construction and characteristics of each of the following: digital tachometer, optical tachometer, induction tachometer, and Hall-offect tachometer.
- 20.10. Discuss the characteristics of stroboscopic methods of measuring rotational velocity.
- 20.11. What are the main types of analogue tachometers available? Discuss the main characteristics of each.
- 20.12. How does a rate gyroscope work? What is its main application?

APPENDIX 1

Imperial-Metric-SI Conversion Tables

Length

SI units: mm, m, km Imperial units: in, ft, mile

	-		lom	in	ft	mile
mm	1	10-3	10-4	0.039 3701	3.281 × 10 ⁻³	-
m	1006	1	10-3	39.3701	3.280 84	6.214 × 10 ⁻⁰
line	104	103	1	39 370.1	3280 84	0 621 371
in	25.4	0.0254		1	0 063 333	
ft	304.8	0.3048	3 048 × 10 4	12	1	L 894 x 10-*
mile	-	1609.34	1.609 34	63 360	5290	1

Area

SI units: mm², m², km² Imperial units: in², ft³, mile²

			in the second second	in the second se		and the second s
Harn 2	1	10-4	-	1.550 × 10-3	1.076 × 10 ⁻⁵	-
m ²	104	1	10-4	1550	10.764	-
time 2	-	104	1	-	1076 x 10 ⁷	0.3861
in ²	645 16	6 452 × 10-4	-	1	6.944 × 10 ⁻³	-
R2	92 903	0 092 90	-	144	1	
rada ²	-	2.590 × 10 ⁶	2.590	-	2.788 × 10 ⁷	1

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Second Moment of Area

SI units: mm⁴, m⁴ Imperial units: in⁴, ft⁴

		- *	in the second seco	h*
mm ⁴	1	10-13	2.4025 × 10 ⁻⁴	1.159 × 10-19
m ⁴	1018 -	1	2.4025 × 10 ⁴	115.86
in ⁴	416 231	4 1623 × 10 ⁻⁷	1	4.8225 × 10-1
1. 1t ⁴	8.631 × 10 ⁹	8.631 × 10 ⁻³	20 736	1

Volume

SI units: mm³, m³ Metric units: ml, l Imperial units: in³, ft³, UK gallon

		mi	I.	-	in'		UK Gallon
an m	1	10-3	10-6	10-9	6.10 × 10 ⁻⁵	-	-
ml	103	1	10-3	10-4	0.061 024	3.53×10^{-1}	2.2 × 10 ⁻⁴
	10 ⁴	103	1	10-3	61.024	0.035 32	0.22
m ^a	10°	106	103	1	61 024	35.31	220
in ³	16 387	16.39	0.0164	1.64 × 10 ⁻⁶	1	5.79 × 10 ⁻⁴	3.61 × 10 ⁻³
R3	-	2.83 × 10 ⁴	28.32	0.028 32	1728	1	6.229
UK gallos		4546	4.546	4.55×10^{-3}	277.4	0_1605	1

Note: Additional unit 1 US gallon = 0.8327 UK gallon

Density

SI unit: kg/m³ Metric unit: g/cm³ Imperial units: Ib/ft³, Ib/in³

	lig/m	g/cm	An/At ³	Na/ In
kg/m ³	1	10 3	0.062 428	3 605 × 10 5
g/cm ⁸	1000	1	62.428	0.036 127
lb/tt ¹	16.019	0.016 019	1	5.787 × 10 ⁻⁴
lin/in ³	27 680	27.680	1728	1

Mass

SI units: g. kg. t Imperial units: lb, cwt, ton

		in the second	t		CHIE	Same .
	1	10-1	10-6	2.205 × 10-1	1.968 × 10 ⁻¹	9.842 × 10-7
kar	103	1	10-3	2 204 62	0.019 684	9.842 × 10
t	104	101	1	2204 62	19.6841	0 964 207
Ib	453.592	0.453 59	4 536 x 10 4	1	8.929 = 10 ⁻³	4.464 × 10 ⁻⁴
CWE	50 802.3	50.6023	0.050 802	112	1	0.05
ton	1.016 × 10 ⁶	1016.05	1.01605	2240	20	1

Force

SI units: N, kN Metric unit: kg, Imperial units: pdl (poundal), lb, UK ton;

	N	-	IdN	pill .	lity	LIK mm
N	1	0 1020	10-3	7 233	0.2248	1.004 x 10 ⁻⁴
line,	9.807	1	9.807 x 10 ⁻³	70.93	2.2046	9.842 × 10 ⁻⁴
kN	1000	102.0	1	7233	224.8	0.1984
pdl	0 1383	0.0141	1 383 × 10 4	1	0.0311	1.365 = 10-1
lb,	4.448	0 4536	4.448 = 10-3	32,174	1	4.464 = 10-4
UK ton	9964	1016	9.964	72 070	2240	1

Note Additional unit: 1 dyns = 10^{-6} N = 7.233 × 10^{-1} pdl.

Torque (Moment of Force)

SI unit: N m Metric unit: kgr m Imperial units: pdl ft, lbr ft

	Nm	lig, m	pil R	lin, ft
Nm	1	0 1020	23.73	0.7376
lan. en	9,807	1	232.7	7.233
nd it	0.042 14	4.297 × 10 ⁻³	1	0.031 08
Ib, ft	1.356	0.1383	32.17	1

Inertia

SI unit: N m² Imperial unit: lb_f ft²

 $1 \text{ lb}_{f} \text{ } \text{f}^{2} = 0.4132 \text{ N m}^{2}$ $1 \text{ N m}^{2} = 2.420 \text{ lb}_{f} \text{ } \text{f}^{2}$

Pressure

SI units: mbar. bar, N/m² (pascal) Imperial units: lb/in², in Hg. atm

	mber	ber	N/m ^a	lin/in*	us Hg	-
mbar	1	10-3	100	0.014 50	0.029 53	9 869 × 10 4
ber	1000	1 1	105	14.50	29.53	0.9869
N/m ²	0.01	10-5	1	1.450 × 10 ⁻⁴	2 953 × 10-4	9.869 × 10 ⁻⁶
lb/in ²	68.95	0.868 95	6895	1	2.036	0.065 05
in Hg	33.86	0.033 86	3386	0.4912	1	0.033 42
atm	1013	1.013	1.013×10^{5}	14.70	29.92	1

Additional Conversion Factors

1 inch water = 0.073 56 in Hg = 2.491 mbar 1 torr = 1.333 mbar 1 pascal = 1 N/m^2

Energy, Work, Heat

SI unit: J Metric units: kg, m, kW h Imperial units: ft lb_r, cal, Btu

	J		kw h	At By	cal	(item
j	1	0 1020	2.778 × 10 ⁻⁹	0.7376	0 2368	9.478 x 10 °
ligy m	9.8066	1	2.724 × 10 ⁻⁶	7.233	2 342	9.294 x 10 °
kw la	3.600 × 10 ⁸	367 098	1	2.655 × 10 ⁴	859 845	3412.1
ft lby	1.3558	0 1383	3.766 × 10 ⁻⁷	1	0.3230	1.265 x 10 °
cal	4.1866	0 4270	1.163 × 10 ⁻⁶	3.0880	1	3.968 x 10 °
Btu	1055.1	107 59	2.931 × 10 ⁻⁴	778.17	252.00	1

Additional Conversion Factors

1 therm = 10^{5} Btu = 1.0551×10^{8} J 1 thermie = 4.186×10^{6} J 1 hp h = 0.7457 kW h = 2.6845×10^{6} J 1 ft pdl = 0.042 14 J 1 erg = 10^{-7} J

Power

SI units: W. kW Imperial units: HP, ft lb₀/s

	W	kw	HP	ft lbg/n
W	1	10-3	1.341 × 10 ⁻³	0.735 64
KW	103	1	1.341 02	735.64
HP	745.7	0.7457	1	548.57
ft Iby/s	1.359 35	1.359×10^{-3}	1.823×10^{-3}	1

Velocity

SI units: mm/s, m/s Metric unit: km/h Imperial units: ft/s, mile/h

	smm/a	m/a	Jum/h	R/s	mile/h
ID/TI/S	1	10-3	3.6 × 10 ⁻³	3.281 × 10 ⁻³	2.237 × 10-3
m/s	1000	1	3.6	3.280 84	2.236 94
lom/h	277.778	0.277 778	1	0.911 344	0.621 371
R/s	304.8	0 3048	1.097 28	1	0.681 818
mile/h	447 04	0.447 04	1.609 344	1.466 67	1

Acceleration

SI unit: m/s² Other metric unit: cm/s² Imperial unit: ft/s² Other unit: g

	m/x ^x	m/ 1 ⁸	6/1 ²	8
m/s ²	1	100	3.281	0.102
cm/s ²	0.01	1	0.0328	0.001 02
fk/s ²	0.3048	30.46	1	1
2	9.81	981	32.2	1

Mass Flow Rate

SI unit: g/s Metric units: kg/h, tonne/d Imperial units: lb/s, lb/h, ton/d

		lig/h	tonne/d	No/B	iliy k	texes/d
g/s	- 1	3.6	0.086 40	2.205 × 10 ⁻³	7.937	0.085 03
lig/h	0.2778	1	0.024 00	6.124 × 10 ⁻⁴	2 205	0.023 62
tonne/d	11.57	41.67	1	0.025 51	91.86	0.9842
lb/s	453.6	1633	39.19	1	3600	38.57
lb/h	0 1260	0.4536	0.010 89	2.788 × 10 ⁻⁴	1	0.010 71
ton/d	11.76	42.34	1.016	0.025 93	93.33	1

Volume Flow Rate

SI unit: m³/s Metric units: l/h, ml/s Imperial units: gal/h, ft³/s, ft³/h

	1/h	mi/s	m¹/ 0	gal/%	R ² /0	ft?/h
l/h	1	0.2778	2.778 × 10-7	0 2200	9.810 × 10-4	0.035 316
ml/s	3.6	1	10-4	0.7919	3 532 × 10-4	0.127 14
m ³ /s	3.6 × 10 ⁶	106	1 1	7.919 × 10 ⁶	35.31	1.271 × 10 ³
gal/h	4.546	1 263	1 263 × 10 ⁻⁰	1	4.460 x 10 ⁻⁵	0.160 56
ft ³ /s	1.019 × 10 ⁵	2.832 × 104	0.028 32	2.242 × 104	1	3600
ft ³ /h	28.316	7 8653	7.865 × 10 ⁻⁶	6.2282	2.778 × 10 ⁻⁴	1

Specific Energy (Heat per Unit Volume)

SI units: J/m³, kJ/m³, MJ/m³

Imperial units: kcal/m³, Btu/ft³, therm/UK gal

	3/=	lig/m ³	Mj/m ¹	hand/m ²	Bm/R ³	therm/UK gal
1/m ³	1	10-3	10-*	1.385 × 10 ⁻⁴	2.684 × 10 ⁻⁵	-
ld/m ³	1000	1	10-3	0.2386	0.02684	-
A4I/m ^b	10 ⁶	1000	1	238.8	26.84	4.309 x 10 ⁻⁶
hen/m	4187	4.187	4.187 × 10 ⁻³	1	0.1124	1.804 × 18
Bbu/R ³	3.726 × 10*	37.26	0.03726	8.899	1	1.605 × 18 *
therm/UK gal	-	-	2.321 × 10 ⁴	5.543×10^{8}	6.229 × 10 ⁵	1

Dynamic Viscosity

SI unit: N s/m² Metric unit: cP (centipolae), P (poise) [1 P = 100 g/m =] Imperial unit: lb_m/ft h

-	lb _m /ft h	P	dP	N s/m ²
lb _m /ft h	1	4.133 x 10 ⁻³	0.4134	4.134 × 10 ⁻⁴
Р	241.9	1	100	0.1
сP	2.419	0.01	1	10-1
N s/m ²	2419	10	1000	1

Note Additional unit: 1 pascal second = 1 N s/m²

Kinematic Viscosity

SI unit: m²/s Metric unit: cSt (centistokes), St (stokes) Imperial unit: ft²/s

	Rt/s	m ¹ /0	dit	8
ft ² /s	1	0.0929	9.29 × 10 ⁴	929
m ² /s	10.764	1	10 ⁶	104
cSt	1.0764 × 10 ⁻¹¹	10 ⁻⁶	1	0.01
St	1.0764 × 10 ⁻³	10 ⁻⁶	100	1

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1

APPENDIX 2

Thevenin's Theorem

Thevenus's theorem is extremely useful in the analysis of complex electrical circuits. It states that any actwork that has two accessible terminals. A and B, can be replaced, as far as its external behavior is concerned, by a single e.m.f. acting in series with a single resistance between A and B. The single equivalent e.m.f. is that e.m.f. measured across A and B when the circuit external to the network is disconnected. The single equivalent resistance is the resistance of the network when all current and voltage sources within it are reduced to zero. To calculate this internal resistance of the network, all current sources within it are treated as open circuits and all voltage sources as short circuits. The proof of Thevenin's theorem can be found in Skilling (1967).

Figure A2.1 shows part of a network consisting of a voltage source and four resistances. As far as its behavior external to terminals A and B is concerned, this can be regarded as a single voltage source, V_i , and a single resistance, R_i . Applying Thevenin's theorem, R_i is found first of all by treating V_1 as a short circuit, as shown in Figure A2.2. This is simply two resistances, R_1 and $(R_2 + R_4 + R_5)$, in parallel. The equivalent resistance, R_i , is thus given by

$$K_t = \frac{R_1(R_2 + R_4 + R_5)}{R_1 + R_2 + R_4 + R_5},$$







where V_t is the voltage drop across AB. To calculate this, it is necessary to carry out an intermediate step of working out the current flowing, *I*. Referring to Figure A2.1, this is given by

$$I = \frac{V_1}{R_1 + R_2 + R_4 + R_5}.$$

Now, V_i can be calculated from

$$V_{t} = I(R_{2} + R_{4} + R_{5})$$
$$= \frac{V_{1}(R_{2} + R_{4} + R_{5})}{R_{1} + R_{2} + R_{4} + R_{5}}$$

The network of Figure A2.1 has thus been reduced to the simpler network shown in Figure A2.3,

Let us now proceed to the typical network problem of calculating the current flowing in resistor R_3 of Figure A2.4. R_3 can be regarded as an external circuit or load on the rest of the





network consisting of V_1 , R_1 , R_2 , R_4 , and R_5 , as shown in Figure A2.5. This network of V_1 , R_1 , R_2 , R_4 , and R_5 is that shown in Figure A2.6. This can be rearranged to the network shown in Figure A2.1, which is equivalent to the single voltage source and resistance, V_i and R_5 , calculated earlier. The whole circuit is then equivalent to that shown in Figure A2.7, and the current flowing through R_3 can be written as

$$I_{AB} = \frac{V_i}{R_i + R_3}$$











Thevenin's theorem can be applied successively to solve ladder networks of the form shown in Figure A2.8. Suppose in this network that it is required to calculate the current flowing in branch XY.

The first step is to imagine two terminals, A and B, in the circuit and regard the network to the right of AB as a load on the circuit to the left of AB. The circuit to the left of AB can be reduced to a single equivalent voltage source, E_{AB} , and resistance, R_{AB} , by Thevenin's theorem. If the 50-V source is replaced by its zero internal resistance (i.e., by a short circuit), then R_{AB} is given by

$$\frac{1}{R_{AB}} = \frac{1}{100} + \frac{1}{2000} = \frac{2000 + 100}{200,000}.$$

Hence,

 $R_{AB} = 95.24 \,\Omega.$

When AB is open circuit, the current flowing round the loop to the left of AB is given by

$$I = \frac{50}{100 + 2000}$$
.





Hence, EAR, the open circuit voltage across AB, is given by

$$E_{AB} = 1 \times 2000 = 47.62$$
 volts.

We can now replace the circuit shown in Figure A2.8 by the simpler equivalent arcuit shown in Figure A2.9,

The next stage is to apply an identical procedure to find an equivalent circum consisting of voltage source $E_{A'B'}$ and resistance $R_{A'B'}$ for the network to the left of points *a* and *B'* in Figure A2.9:

$$\frac{1}{R_{AB}} = \frac{1}{R_{AB} + 150} + \frac{1}{1000} = \frac{1}{245.24} + \frac{1}{1000} = \frac{1245.24}{245.240}.$$

Hence.

$$R_{AW} = 196.94 \,\Omega$$

$$E_{RB} = \frac{1000}{R_{AB} + 150 + 1000} \times E_{AB} = 38.24$$
 volts.

The circuit can now be represented in the yet simpler form shown in Figure A210. Proceeding as before to find an equivalent voltage source and resistance, $E_{A^*B^*}$ and R_{A^*P} , for the circuit to the left of A^* and B^* in Figure A2.10:



$$\frac{1}{R_{A'B'}} = \frac{1}{R_{A'B'} + 250} + \frac{1}{500} = \frac{500 + 446.94}{223,470}$$

Hence,

 $R_{A'B'} = 235.99 \,\Omega$

$$E_{A^*B^*} = \frac{500}{R_{A^*B^*} + 250 + 500} E_{A^*B^*} = 20.19$$
 volts.

The circuit has now been reduced to the form shown in Figure A2.11, where the current through branch XY can be calculated simply as

$$I_{RT} = \frac{E_{A^*B^*}}{R_{A^*B^*} + 300 + 200} = \frac{20.19}{735.99} = 27.43 \text{ mA}.$$



Figure A2.11

Reference

Skilling, H.H. (1967). Electrical engineering circuits. Wiley: New York

APPENDIX 3

Thermocouple Tables

1

Type E: chromel-constantan Type J: iron-constantan Type K: chromel-alumel Type N: nicrosil-aisil Type S: platinum/10% rhodium-platinum Type T: copper-constantan

Timp-("C)	Type E	There J	Тури К	Type N	Type S	Tippe T
-270	-9.834		-6.458	-4.345		
- 260	-9.795		-6.441	-4.336	1000	
-250	-9.719		-6.404	-4.313		
-240	-9.604		-6.344	-4.277		-6,105
-230	-9.456		-6.262	-4.227		-6 803
-220	-9.274		-6.158	-4.162		-5.891
-210	-9.063	-8.096	-6.035	-4.083		-5,753
-200	-8.824	-7.890	-5.891	-3.990		-5.603
- 190	-8.561	-7.659	-5.730	-3.884		-5.438
-180	-8.273	-7.402	-5.550	-3.766		-5.261
-170	-7.963	-7.122	-5.354	-3.634		-5.070
-160	-7.631	-6.821	-5.141	-3.491		-4.865
	-7.279	-6.499	-4.912	-3.336		-4.648
-140	-6.907	-6.159	-4.669	-3.170		-4.419
-130	-6.516	-5.801	-4.410	-2.994		-4.177
-120	-6.107	-5.426	-4.138	-2.807		-3.923
-110	-5.680	-5 036	-3.852	-2.612		-3.656
-100	-\$.237	-4.632	-3.553	-2.407		-3.378
-90	-4.777	-4.215	-3.242	-2.193		-3.000
-80	-4.301	-3.785	-2.920	-1.972		-2.786
-70	-3.811	-3.344	-2.586	-1.744		-2.475
-69	-3.306	-2.892	-2.243	-1.509		-2.152
- 50	-2.787	-2.431	~1.689	-1.268	-0.236	-1.819
-40	-2.254	-1.960	-1.527	-1.023	-0.194	-1.475
-30	-1.799	-1.481	-1.156	-0.772	-0.150	-1.121
-20	-1.151	-0.995	-0.777	-0.510	-0.103	-0.757
-10	-0.581	-0.501	-0.392	-0.260	-0.053	-0,383

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Temp. ("C)	Type E	Type J	Type K	Then N	Type S	Type T
960	73.350	55 553	39.703	34.702	9.126	
970	74.104	56.154	40.096	35.089	9.240	
980	74.857	56.753	40.488	35.476	9.355	
990	75.608	57.349	40.879	35.862	9.470	
1000	76.357	57.942	41.269	36.246	9.585	
1010		58.533	41.657	36.633	9.700	
1020		59.121	42.045	37.018	9.816	
1030		59.708	42.432	37.402	19.932	
1040		60.293	42.817	37.786	10.048	
1050		60.877	43.202	38.169	10.165	
1060		61.458	43.585	38.552	10.282	
1070		62.040	43.968	38,934	10.400	
1080		62.619	44.349	39.315	10.517	
1090		63 199	44.729	39.696	10.635	
1100		63.777	45 106	40.076	10.754	
1110		64 355	45.486	49.455	10.672	
1120		64 833	45 863	27.8.86	10.991	
1130		65 510	46.238	41 213	11,110	
1140		66 087	46 612	41.500	11.229	
1160		66.644	46 985	A1 966	11 348	
1160		67 740	47 356	47 347	11 467	
1170		47 815	47 726	42 717	11 587	
1180		69 189	48.005	43.091	11 707	
1100		48 843	48.462	43.051	11.837	
1200		60 434	48.838	43.454	11 047	
1200		07.330	40.103	43 838	12.067	
1210			49.196	44.207	12.007	
1220			49.333	41.3//	12.100	
1230			47.710	41.947	12.300	
1240			50.270	49.313	12.969	
1250			50 633	45.062	12.330	
1260			50.990	40.040	12.071	
1270			51.344	40.413	12.792	
1280			51.697	46.777	12.913	
1290			52.049	47 140	13.034	
1300			52.398	47.502	13.155	
1310			52.747		13.276	
1320			\$3.093		13.397	
1330			53.438		13.519	
1340			53.782		13.640	
1350			54.125		13.761	
1360			54.467		13.883	
1370			54.807		14.094	
1380					14.125	
1390					14.247	
1400					14.368	
1410					14.489	
1420					14.610	
1430					14.731	1

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		 a state of the second s		2 2 2 2 2	7 7 7
1440				14.852	
1450				14 973	
1460				15.094	
1470				15 215	
1480				15 336	
1490				15 456	
1500				15 576	
1510				15 697	
1520				15 817	
1530				15 837	
1540				16 857	
1550				18 176	
1560		 		16.296	
1570				16 415	
1580	-			16 534	
1590	1			14 453	
1600				14.771	
1610				16.000	
1620				17.008	
1630	[17.195	
1640				17.165	
1650				17 360	
1660				17.300	
1670				17 504	
1680			1	17.374	
1690				17.036	
1700				17 043	
1710		_		17.946	
1720				10.030	
1730				10.170	
1740				10.204	
1750				10.399	
1760				18.504	

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